

# Optoelectronic Components (OC)

**When:** Mon 08:00–09:30 Lecture (beginning 13.04.15)  
Thu 09:45–11:15 Lecture  
Fri 11:30–12:15 Tutorial (beginning 24.04.15)  
Detailed dates and examinations on next page

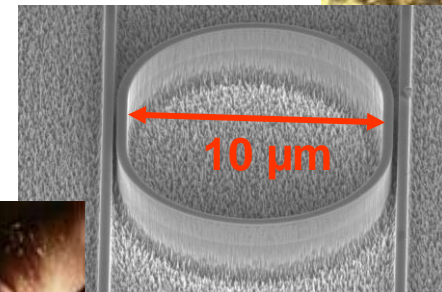
**Where:** Kleiner HS A, Build. 30.22 (L)  
HS II, Build. 30.41 (T)

**Lecturer:** Prof. Dr. W. Freude (Build. 30.10 R.3.34)

**Tutors:** Dipl.-Ing. S. Wolf  
Dipl.-Phys. W. Hartmann

## Contents:

- Optical communications overview
- Slab, strip, and fibre waveguides
- Light-emitting and laser diodes
- Optical amplifiers
- Pin photodiodes
- Noise
- Receivers and detection errors



## Lectures (KI. HS A, Build. 30.22)

1. Mon 13.04.15 08:00
2. Thu 16.04.15 09:45
3. Mon 20.04.15 08:00
4. Thu 23.04.15 09:45
5. Mon 27.04.15 08:00
6. Thu 30.04.15 09:45
7. Mon 04.05.15 08:00
8. Thu 07.05.15 09:45
9. Mon 11.05.15 08:00
10. Mon 18.05.15 08:00
11. Thu 21.05.15 09:45
12. Mon 01.06.15 08:00
13. Mon 08.06.15 08:00
14. Thu 11.06.15 09:45
15. Mon 15.06.15 08:00
16. Thu 18.06.15 09:45

## Tutorial (HS II, Build. 30.41)

*First* Fri 24.04.15 11:30–12:15

*Last* Fri 10.07.15 11:30–12:15

*Total of* 11 tutorials

**A.** Mon 22.06.15 08:00 (Q&A 1)

**B.** Thu 25.06.15 09:45 (Q&A 2)

## Examinations (in my office)

1. Wed 15.07.15 13:00–19:00
2. ??? ???
3. *Aug* none
4. *Normally* once a month

## Lab Tour OC & NLO (IPQ)

1. Tue ???
2. Thu ???



# LECTURE 1



# LECTURE 1 — Introduction

## Why optical communications?

- Based on inexpensive extremely broadband glass fibres
- Fast transmitters with semiconductor lasers
- Fast receivers with semiconductor photodetectors
- Optical broadband amplifiers available

Lightwave technology developed over the last 40 years has greatly influenced our needs for communication. Resources made accessible in the World Wide Web (WWW) have changed our attitude towards information acquisition, which is being regarded as an everyday's necessity, and even as a natural right for everybody. Today's undersea and underground optical cables provide large-capacity links carrying more than 90 % of the communication traffic.





# An Optical Network the Size of a Football Ground

Data centres (Google, Facebook, Microsoft, Apple, . . . )

- Size of a data centre, for example YouTube

100 h video files / min uploaded in May 2013 → 375 PB

Volume increases by 185 TB / d, annual growth rate is 70 %.

540 TB storage per rack & increase for 1 a → 1 200 racks,  
good for 30 000 servers including mass storage of 632 PB.

1 200 racks require an area of  $30\text{ m} \times 100\text{ m} = 3\,000\text{ m}^2$ .

<http://www.autonomoussystem.net/> — Posted 1st July 2013 by Nathan Owens

**Facebook's data center in Luleå, Sweden:** On-line 06/2013



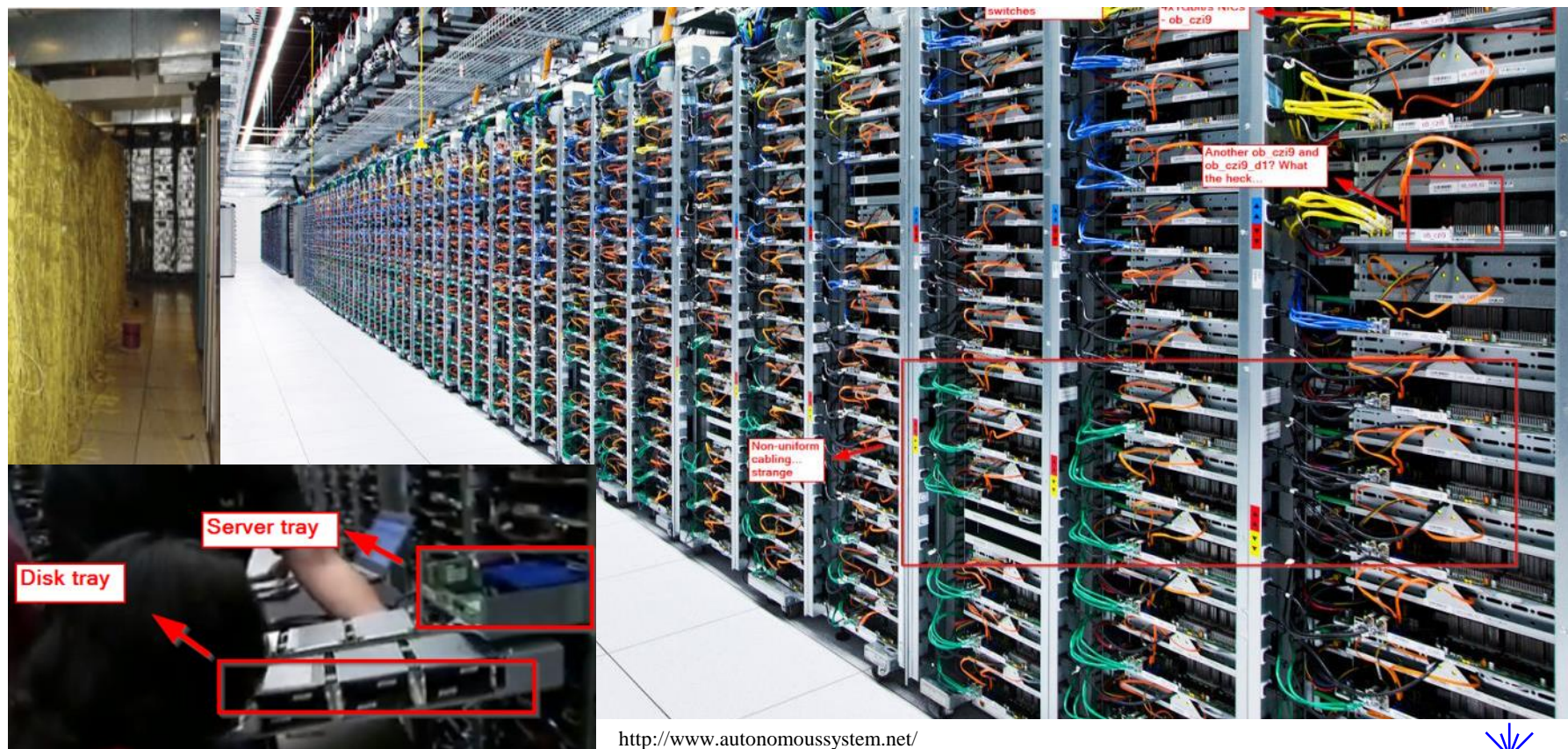
Luleå ['lu:leo]





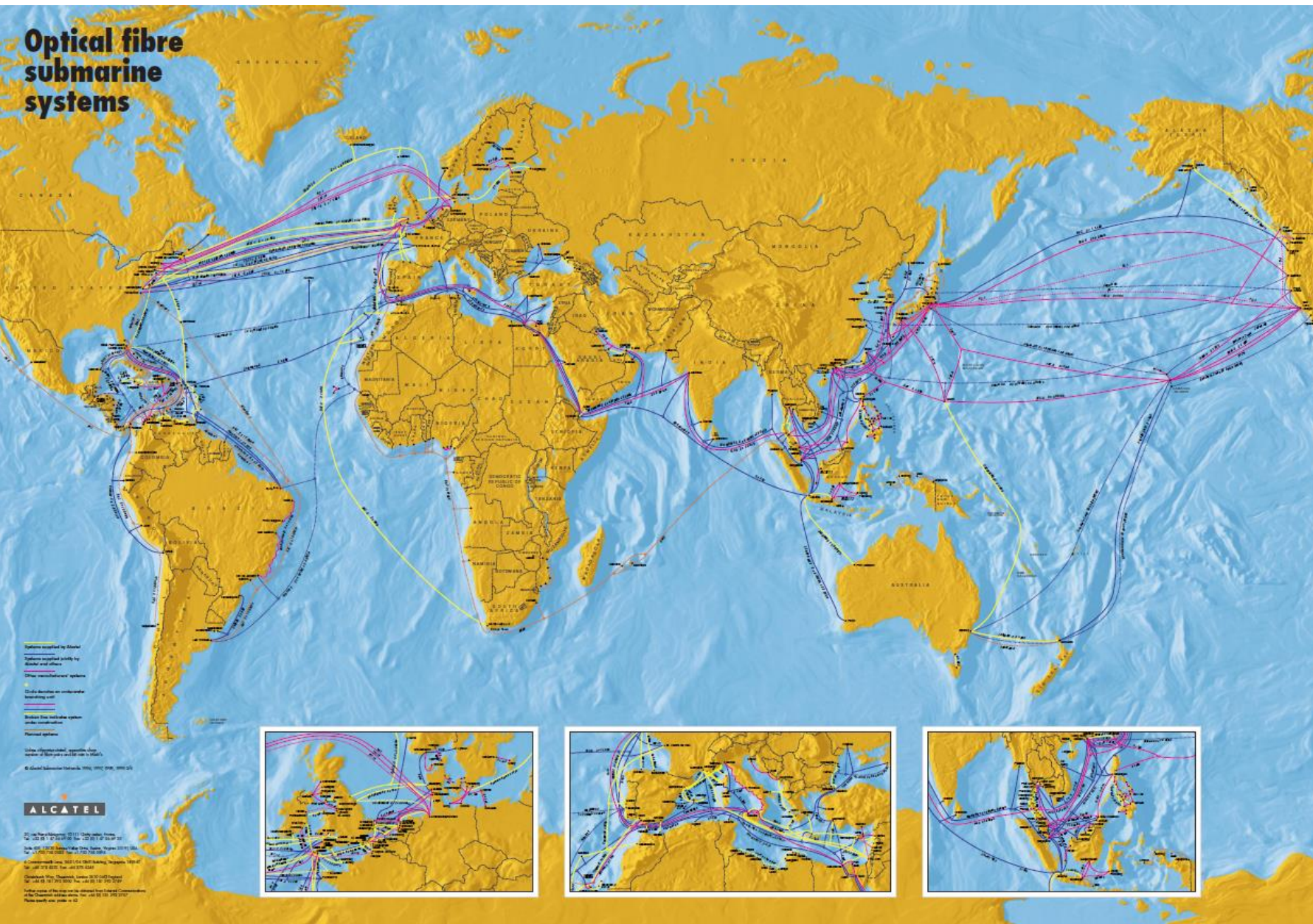
# An Optical Network the Size of a Football Ground — Interior

- **Internal data network** with high-density data traffic  
Server connected by switches with  $30\,000 \times 3 = 90\,000$  10 G-ports,  
i. e., by 90 000 cables, each with a capacity of 10 Gbit/s.  
The aggregate **internal data rate** amounts to **900 Tbit/s**.





# Optical fibre submarine systems





# SUBMARINE CABLE MAP 2007

TeleGeography

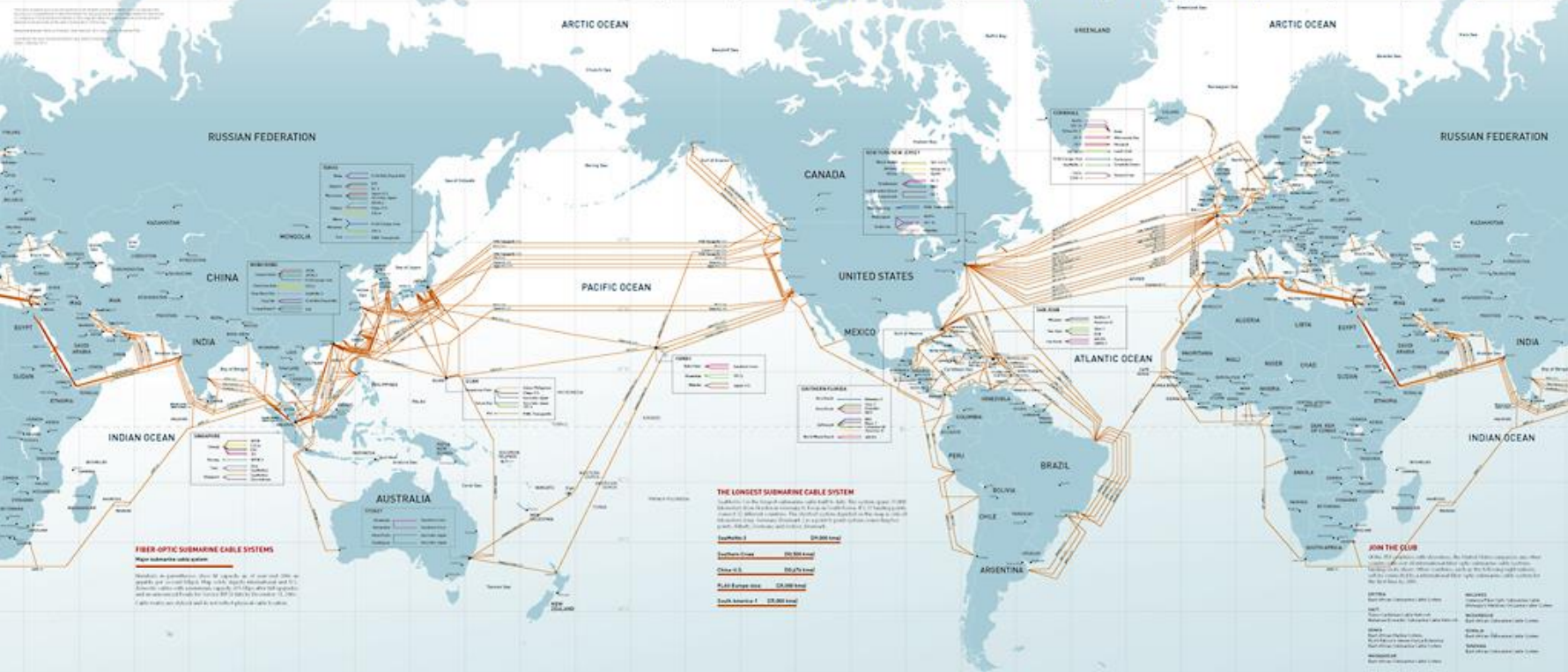
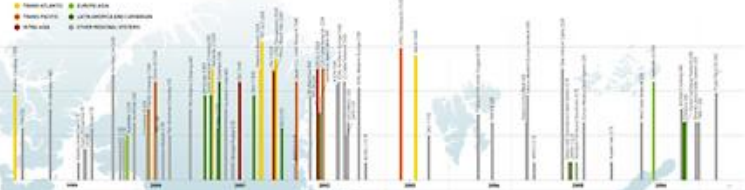


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## SUBMARINE CABLE SYSTEM TIMELINE

This timeline shows the history of submarine cable systems from 1850 to 2007. The chart displays the number of cable systems in operation at the end of each year, categorized by region and type. The regions are: Pacific, Atlantic, Indian, and Arctic. The types are: Fiber-optic, Copper, and Other.



### THE LONGEST SUBMARINE CABLE SYSTEM

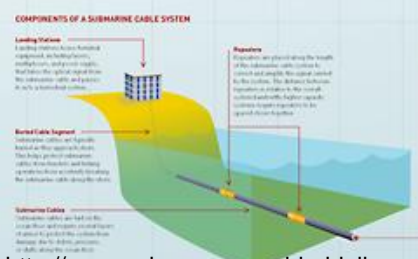
SeaMeWe3 is the longest submarine cable system in the world. It covers over 10,000 kilometers from South Africa to Japan in 10 months. It is a fiber-optic cable system with a capacity of 10.24 Tbit/s.

System Name	Length (km)
SeaMeWe3	10,000
Europe-Asia	10,000
China-US	10,000
Asia-Europe	10,000
South America	10,000

### FIBER-OPTIC SUBMARINE CABLE SYSTEMS

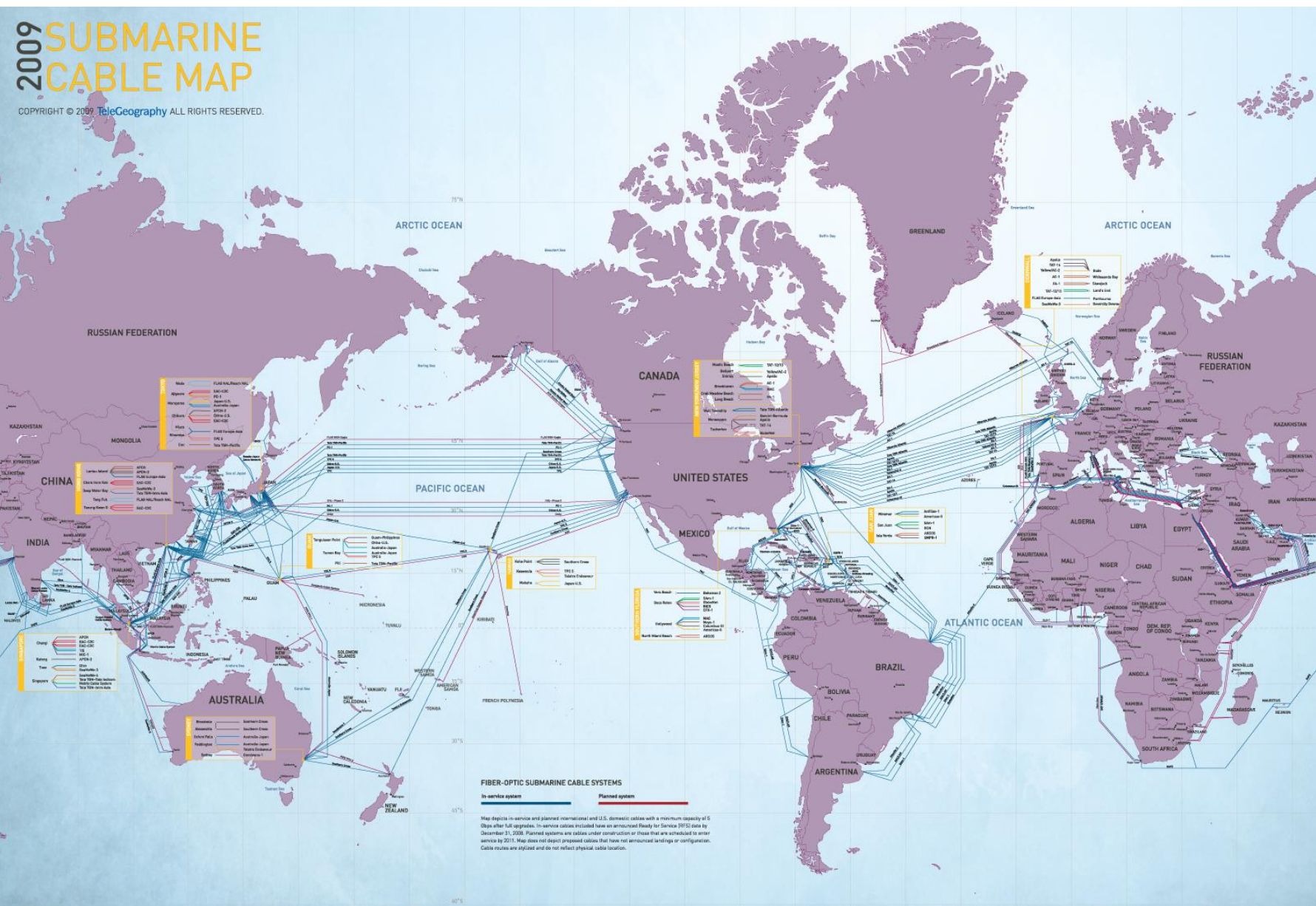
Major submarine cable systems

Introduction of fiber-optic submarine cable systems in the late 1980s and early 1990s revolutionized global telecommunications. These systems provide high-speed, high-capacity data transmission over long distances, significantly reducing latency and increasing bandwidth compared to traditional copper-based systems.



# 2009 SUBMARINE CABLE MAP

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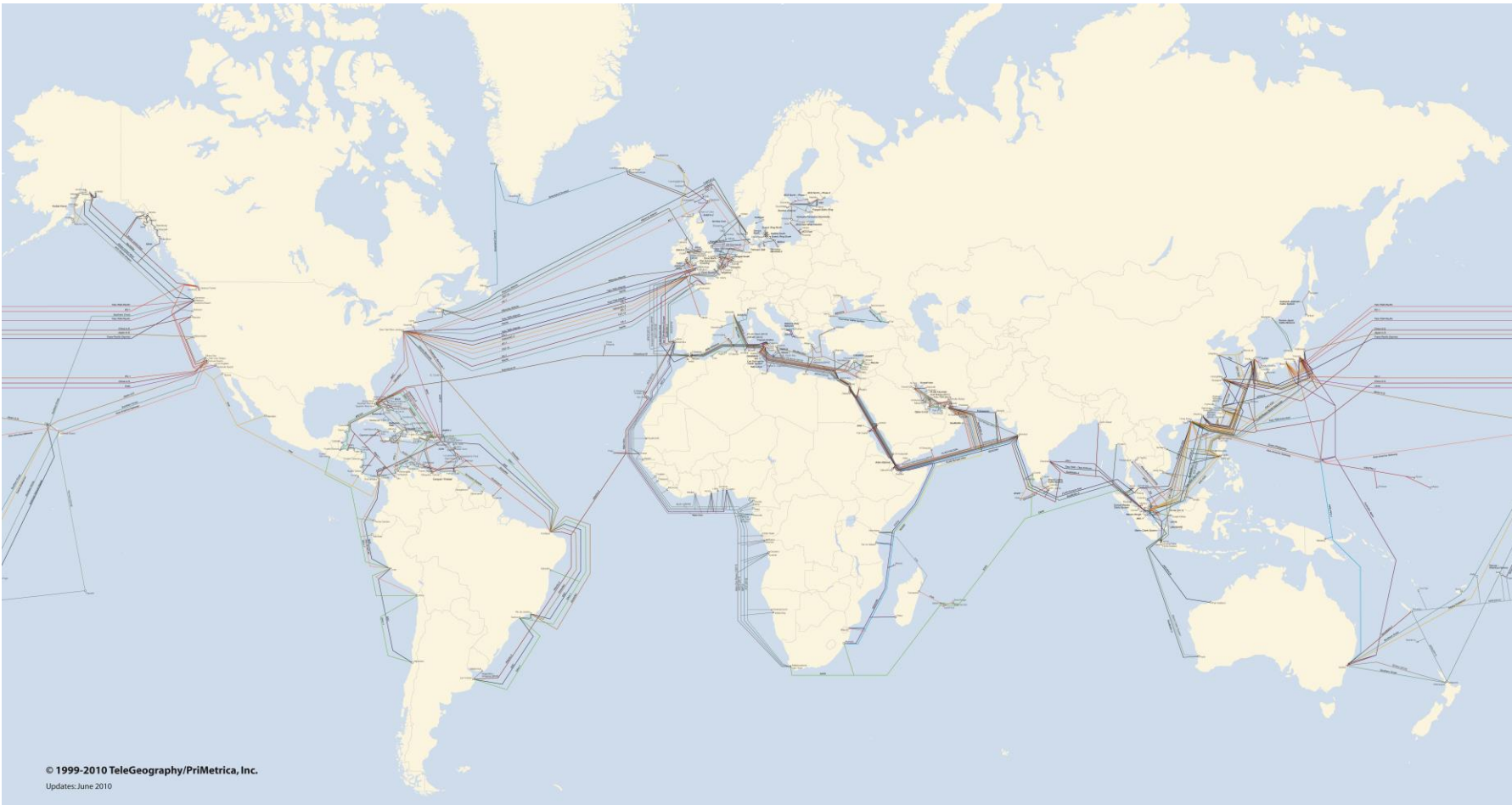
**FIBER-OPTIC SUBMARINE CABLE SYSTEMS**  
 In-service system      Planned system

Map depicts in-service and planned international and U.S. domestic cables with a minimum capacity of 5 Gbps after full upgrades. In-service cables included here are announced Ready for Service (RFS) data by December 31, 2008. Planned systems are cables under construction or those that are scheduled to enter service by 2011. Map does not depict proposed cables that have not announced landings or configuration. Cable routes are stylized and do not reflect physical cable location.

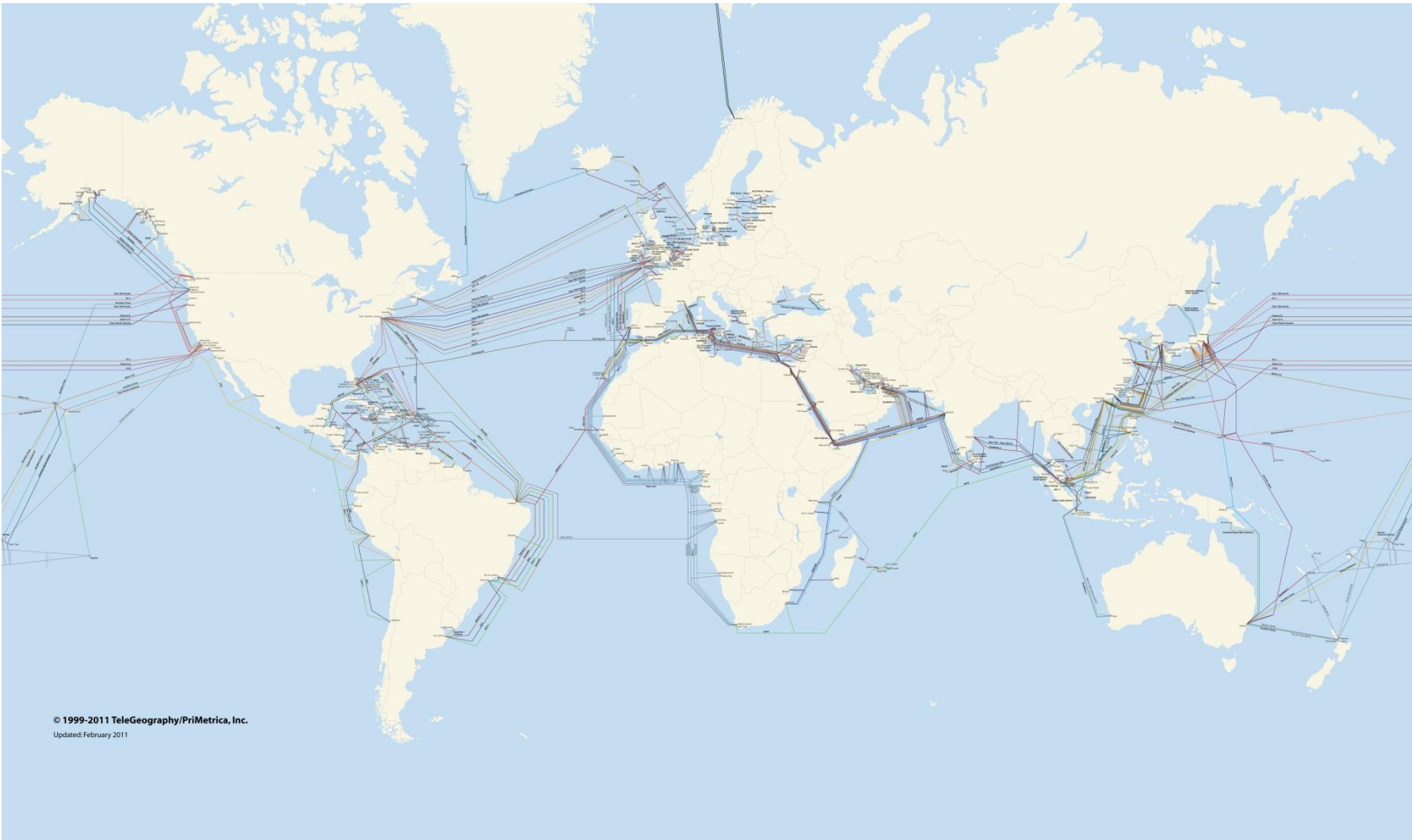




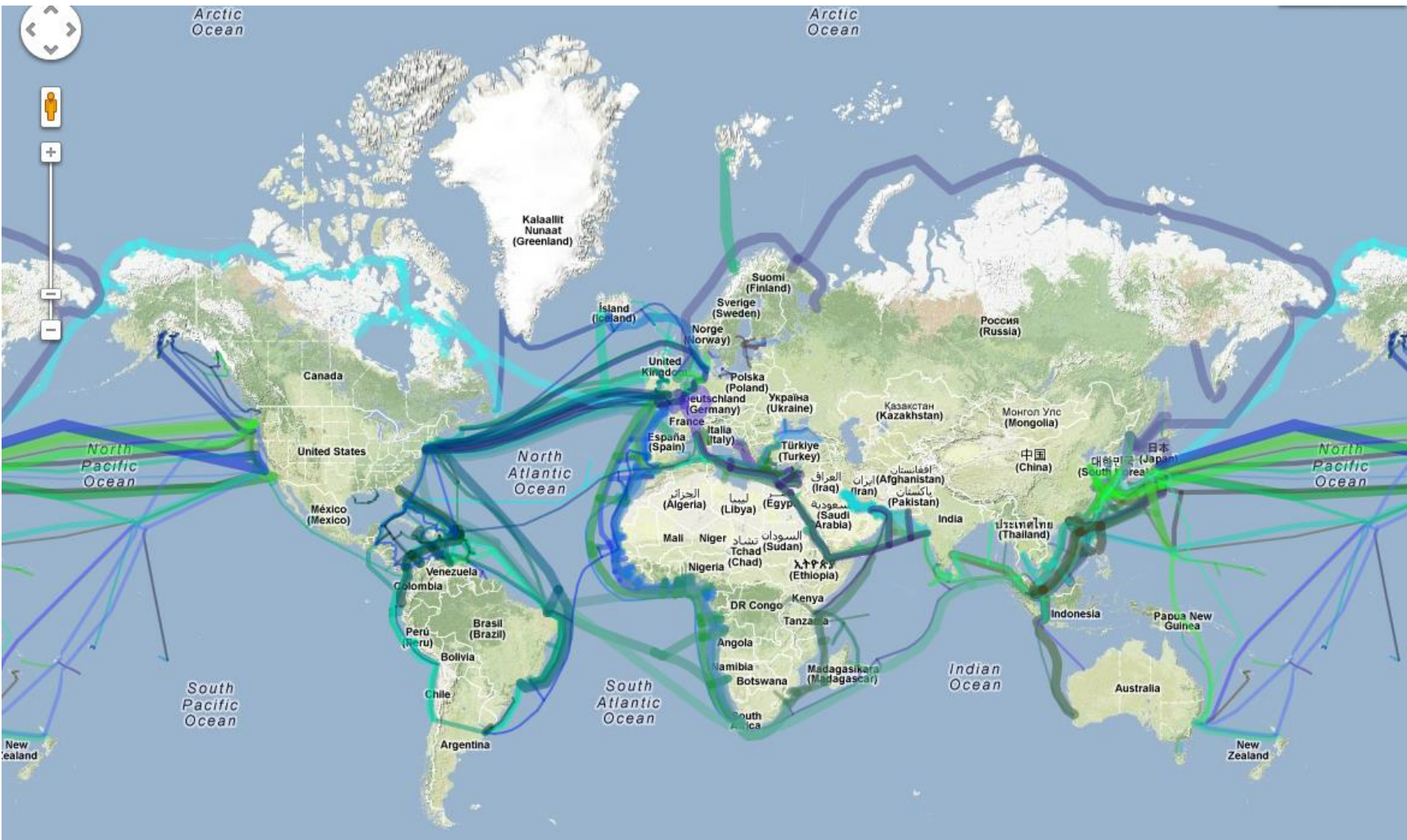
# Submarine Cable Map (2010)



# Submarine Cable Map (2011)

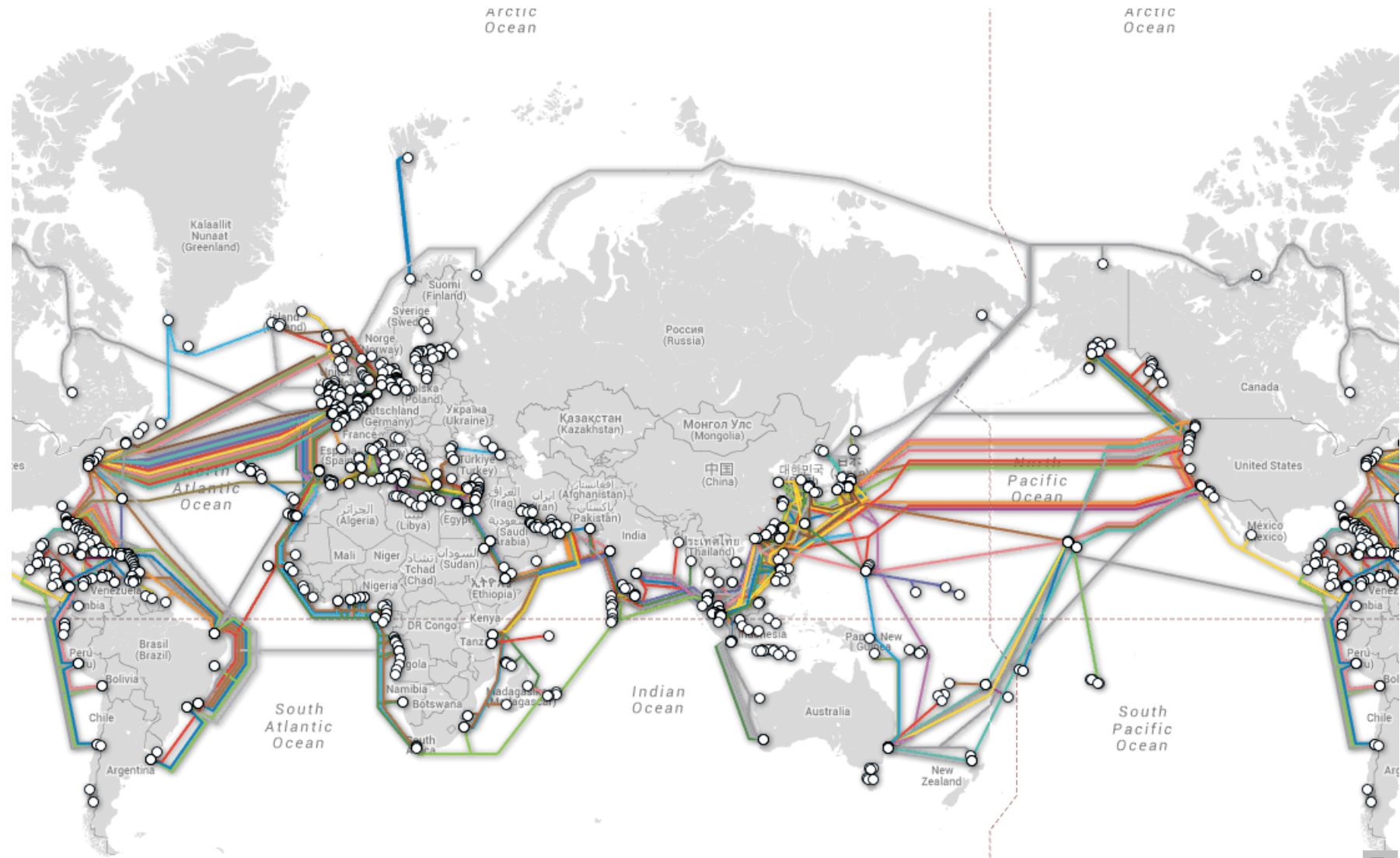


# Submarine Cable Map (2013)





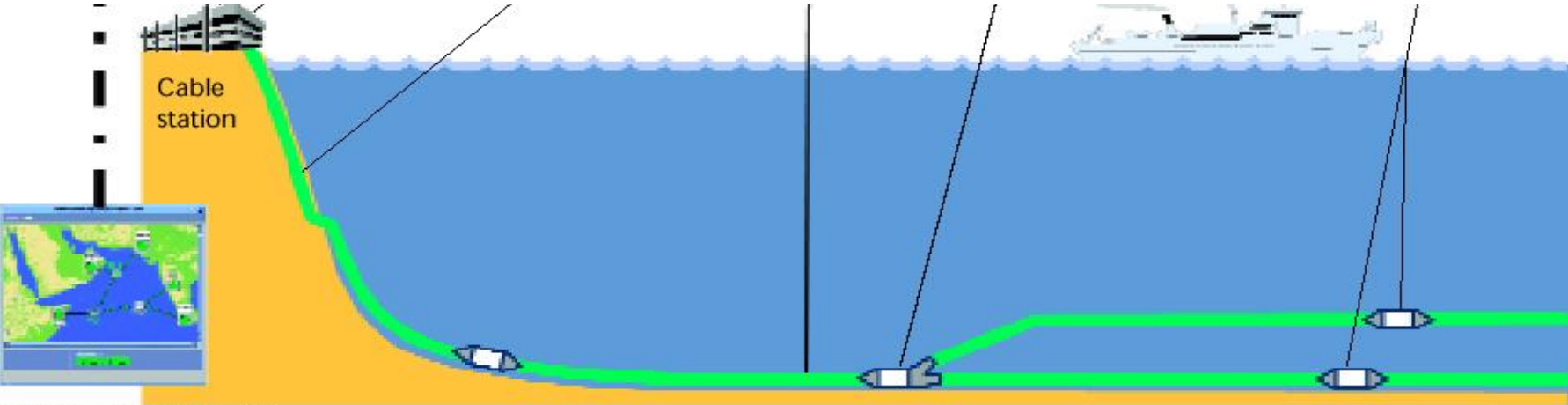
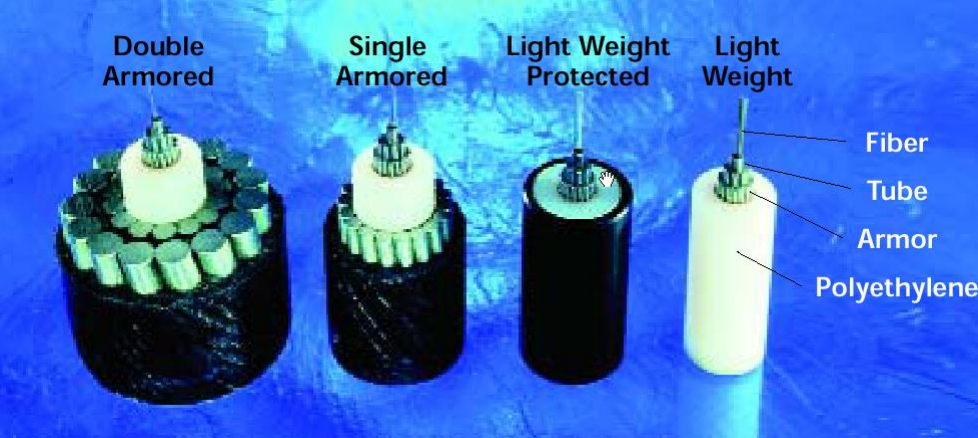
# Submarine Cable Map (2014)



<http://www.submarinecablemap.com/#/>



# Submarine Communication Systems — Laying the Cable



Network management

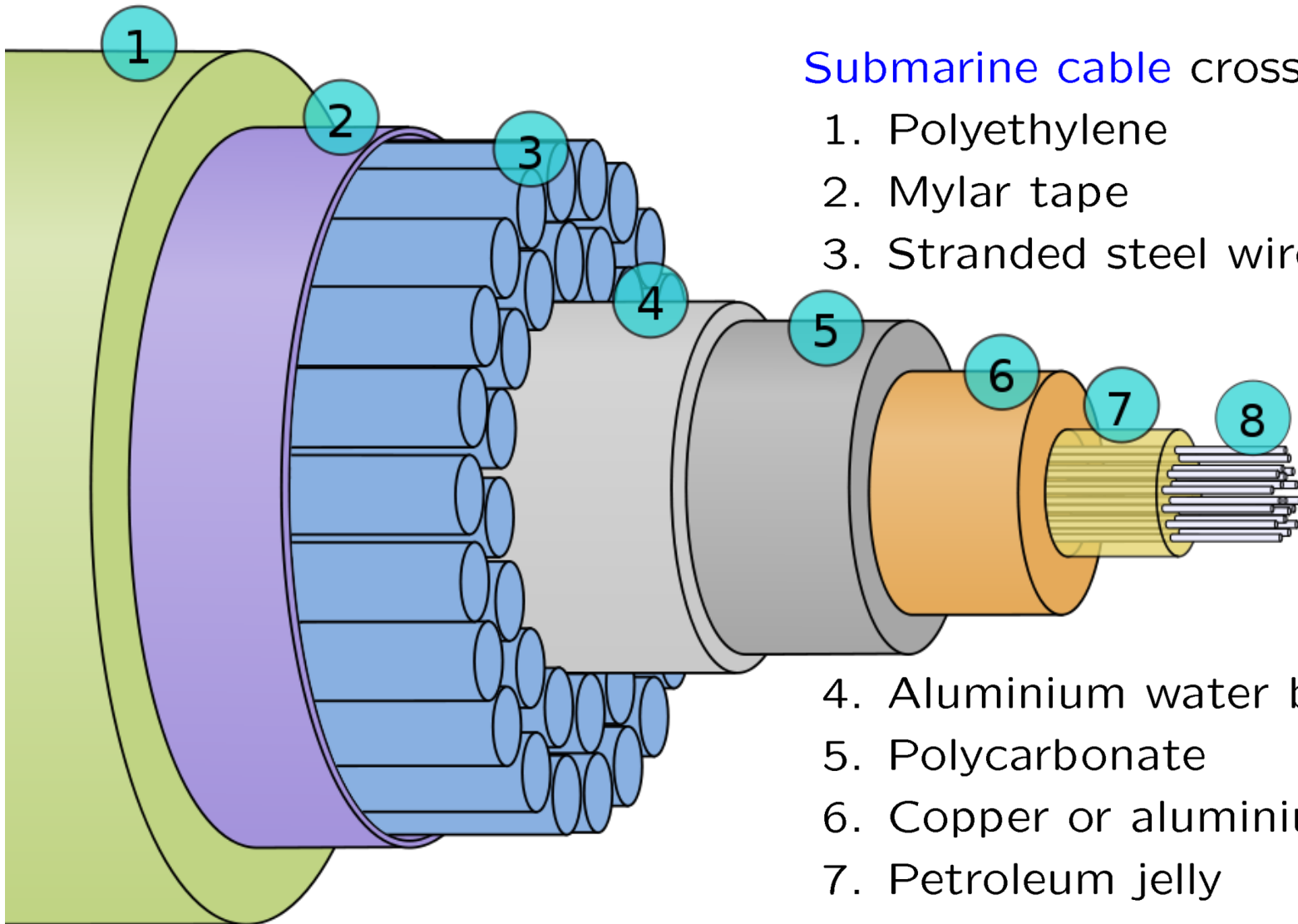


# Submarine Communications Cable

Submarine cable cross-section:

1. Polyethylene
2. Mylar tape
3. Stranded steel wires

4. Aluminium water barrier
5. Polycarbonate
6. Copper or aluminium tube
7. Petroleum jelly
8. Optical fibers



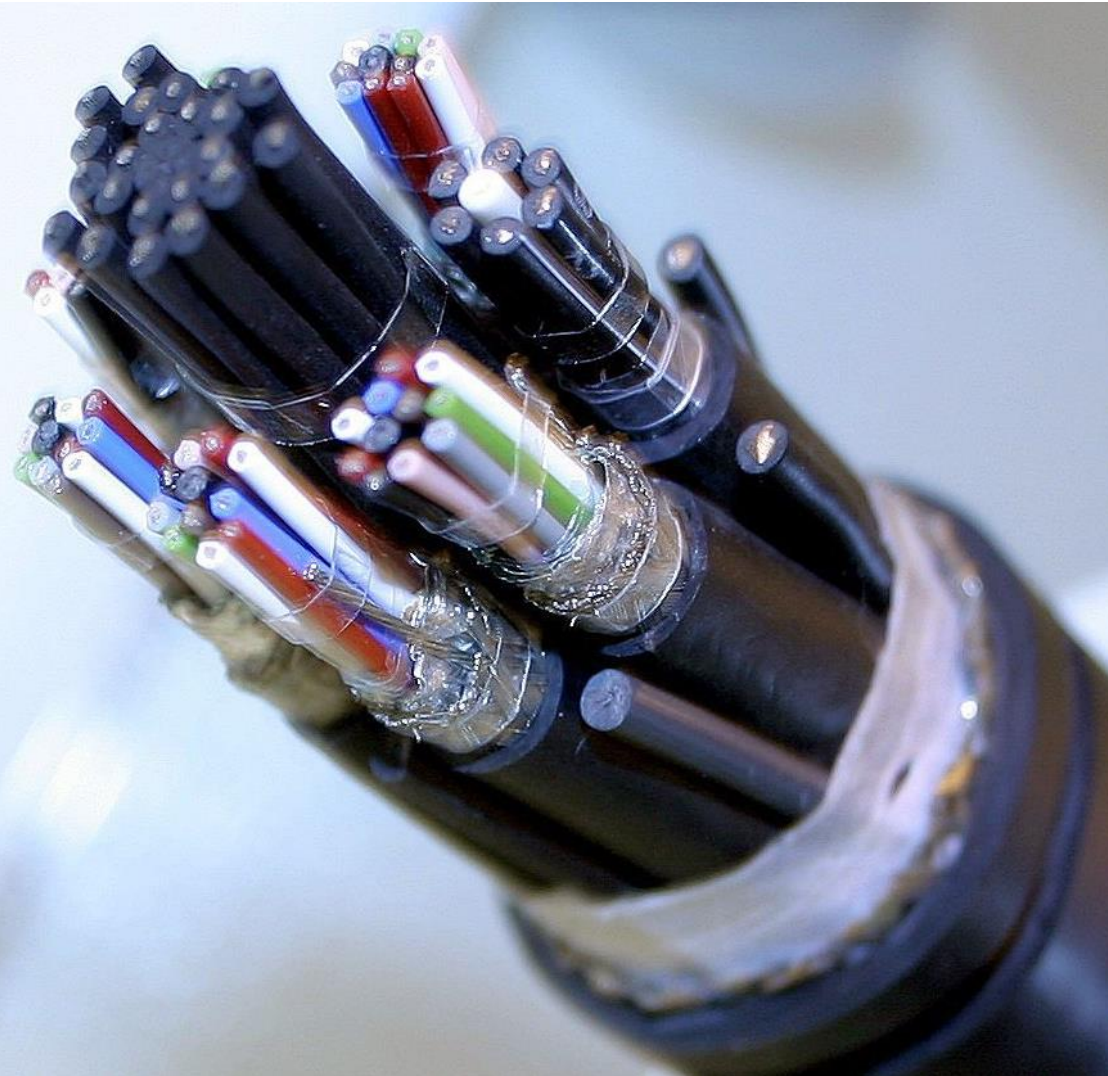


# Submarine Umbilicals

Submarine umbilicals with electrical, optical, hydraulic, mechanical functions for submarine and offshore works

## Umbilical cord

- 1a cord arising from the navel that connects the fetus with the placenta, and through which respiratory gases, nutrients, and wastes pass
- 1b yolk stalk
- 2 tethering or supply line (as for an astronaut outside a spacecraft or a diver underwater)
- 3 necessary, supportive, or nurturing link or connection




# Optical Network Infrastructure — Abbreviations & Buzz Words

SONET Synchronous optical network (ANSI)  
 American National Standards Institute  
 SDH Synchronous digital hierachy (ITU)  
 International Telecommunication Union

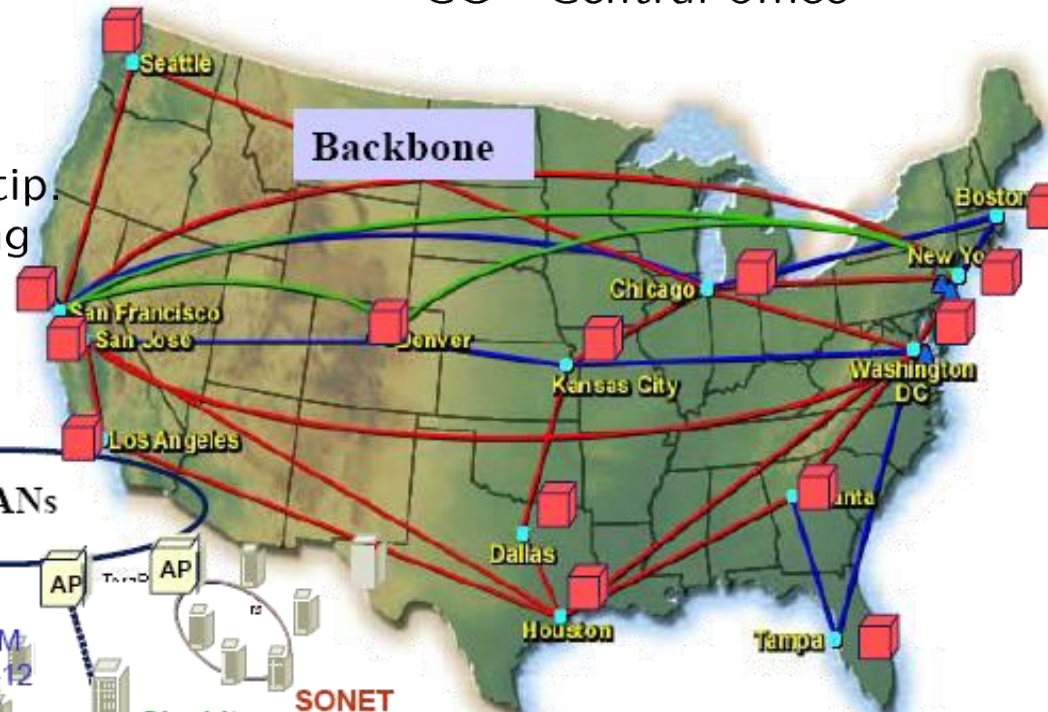
MAN Metropolitan area net.  
 LAN Local area network  
 AP Access point  
 ISP Internet service provdr  
 POP Post office protocol  
 CO Central office

— WDM/TDM fiber links

 Backbone ISP POP, CO

 MAN/LAN Access Point

WDM Wavelength division multip.  
 TDM Time division multiplexing  
 PON Passive optical network  
 FTT $x$  Fibre to the  $x = C, B, H$   
 for **C**abinet, **C**urb,  
**B**uilding, **H**ome



Access by  
 Ethernet  
 RJ45

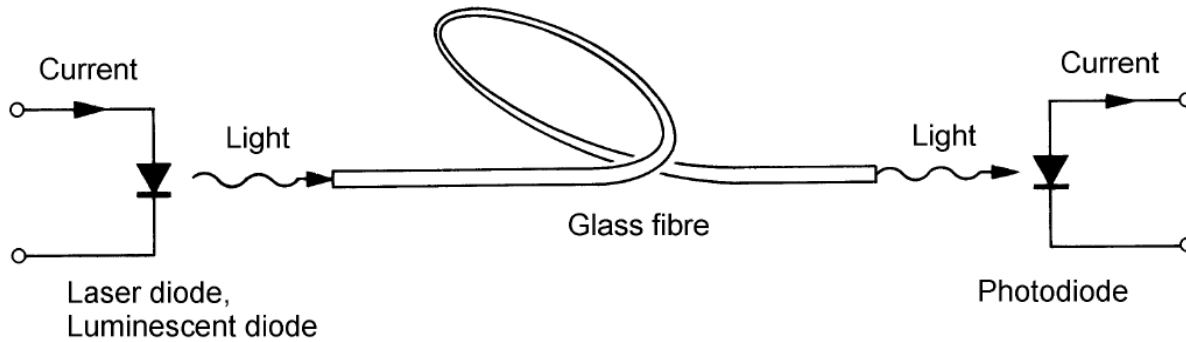


FFTH, FTTC,  
 PON or others.

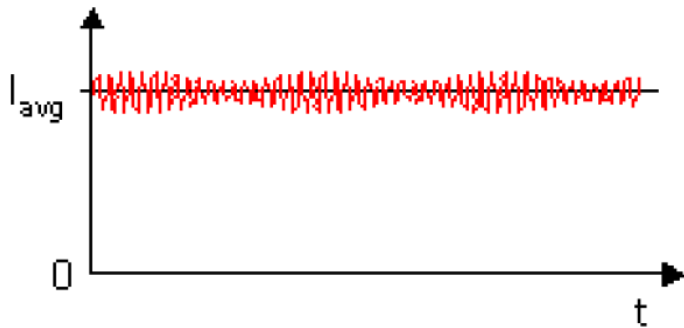
OSI Open system interface  
 Ethernet from "luminiferous  
 aether" (or "ether")



# Communication With Light



**Fig. 1.1.** Optical point-to-point transmission link with an intensity-modulated carrier centered at a wavelength  $\lambda$  and direct (incoherent) detection



(a) Analogue intensity modulation



(b) Digital intensity modulation with TDM

**Fig. 1.2.** Modulation formats (a) Analogue intensity modulation around an operating point  $I_{avg}$  (b) Digital intensity modulation between an off ( $I_0$ ) and an on value ( $I_1$ ). For a 4-channel *time division multiplexing* scheme (TDM) individual transmission time slots 1...4 are assigned to each data source



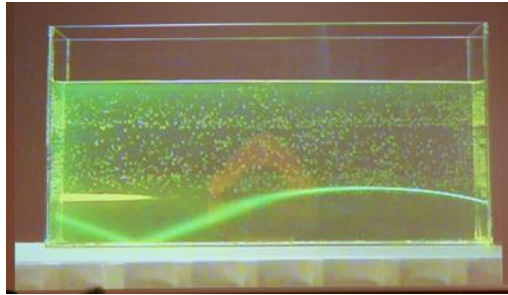


# Light Guidance by Total Internal Reflection or by Index Gradient

**Snell's law** (1621, by Willebrord van Roijen Snell, also called Snellius, ★ 1580 † 1626, Dutch astronomer and mathematician)



**Water with sugar solution** acts as graded-index light guide.



Gießen, H.: Öffentliche Vorlesung über Tarnkappen im Mercedes Museum am 22.7.2008. <http://www.pi4.uni-stuttgart.de/>

**Total internal reflection (TIR)** at transition from optically denser medium (larger refractive index  $n_1$ ) to medium with lesser density (smaller refractive index  $n_2 < n_1$ )

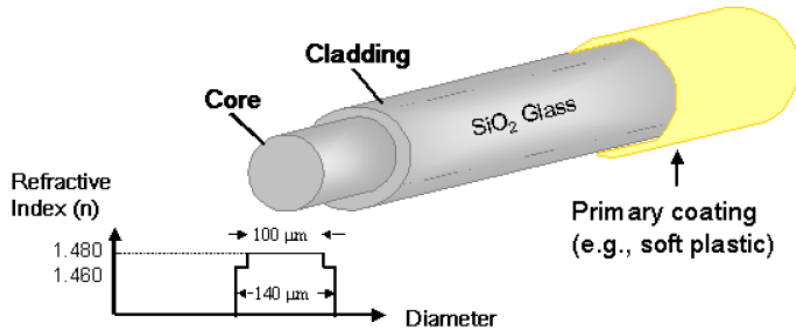


[http://en.wikipedia.org/wiki/File:Total\\_internal\\_reflection\\_of\\_Chelonia\\_mydas\\_.jpg](http://en.wikipedia.org/wiki/File:Total_internal_reflection_of_Chelonia_mydas_.jpg)

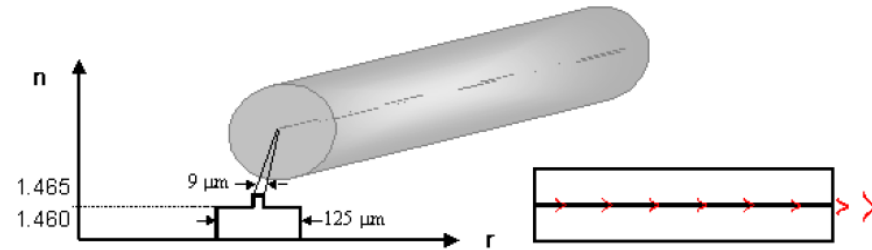
[http://en.wikipedia.org/wiki/File:TIR\\_in\\_PMMA.jpg](http://en.wikipedia.org/wiki/File:TIR_in_PMMA.jpg)



# Fibre Types

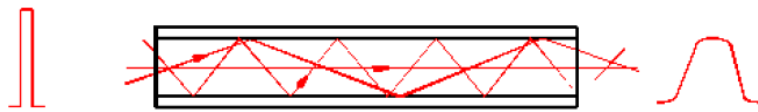


(a) Multimode fibre with step-index profile

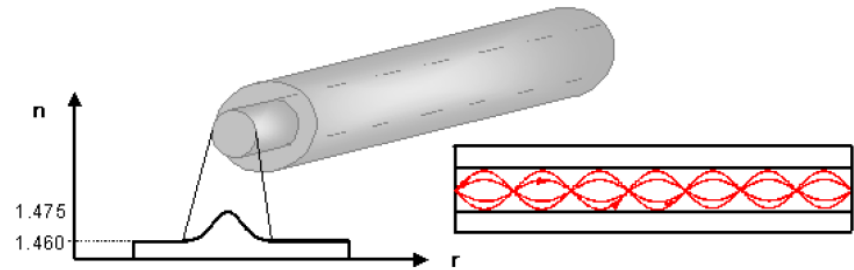


(b) Single-mode fibre with step-index profile

**Fig. 1.3.** Fibre types with step-shaped refractive index profile comprising a higher-index core and a lower-index cladding (a) Fat-core step-index multimode fibre with a relative refractive index difference  $\Delta \approx 1.3\%$  (b) Long-haul step-index single-mode communication fibre with  $\Delta \approx 0.33\%$



(a) Multimode fibre with step-index profile



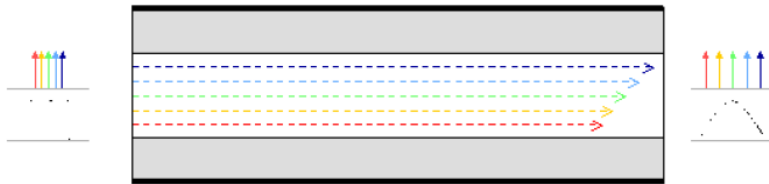
(b) Multimode fibre with graded-index profile

**Fig. 1.4.** Intermodal dispersion for multimode fibres. (a) Step-index profile with significant group delay differences (b) Graded-index profile, where geometrical path length differences are compensated by radial variations in the refractive index

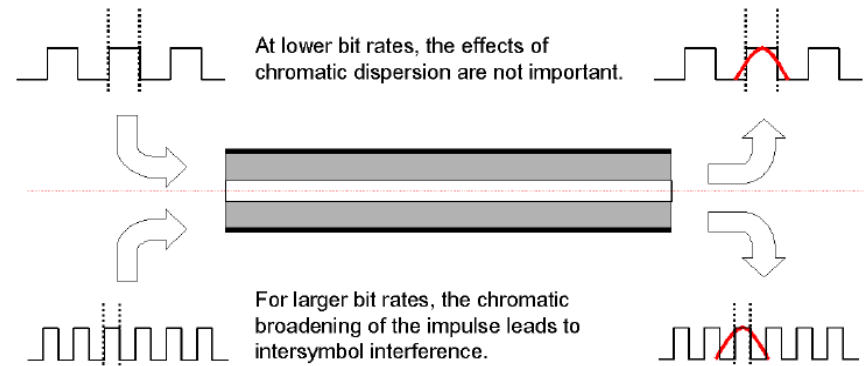




# Chromatic Dispersion



(a) Chromatic dispersion in a single-mode fibre



(b) Group delay dispersion and intersymbol interference

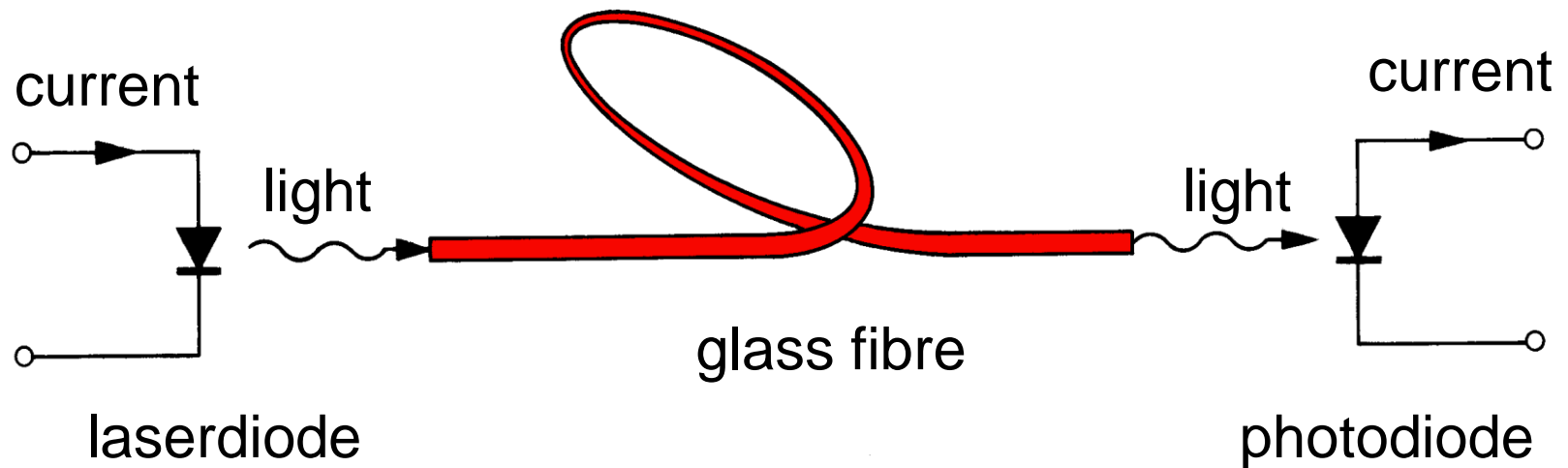
**Fig. 1.5.** Group delay dispersion and bit error probability (bit error rate BER). (a) Different wavelengths (“colours”, therefore “chromatic”) inside the same mode propagate with different velocities, thereby increasing the output impulse width (b) Broadening of the transmitted impulse leads to bit detection errors



# Optical Communications

Rapid extension of internet communication requires systems having higher transmission capacity.

Demands increase 100 % to 200 % per year. Systems are based on **photonic networks with WDM technology** (wavelength division multiplexing).



# Services and Available Bitrates

## Bitrates of typical services:

Voice (ISDN) 64 kbit/s (compressed < 10 kbit/s)

Picture (TV) 140 Mbit/s (compressed 2...6 Mbit/s)

**Loss:** 40 % for 10 km quartz glass fibre (like 20 m coax cable)

## Bitrates of transmission media:

Twisted pair 6 Mbit/s (6 km); coax 650 Mbit/s (1.5 km)

Glass fibre 40 Gbit/s (1 Mio km) Bell / IPQ 2002

Glass fibre 1.28 Tbit/s single channel (240 km) HHI 2006

**Fibre+OFDM 13.5 Tbit/s** 135 OFDM ch (6 248 km) NTT 2009

**Fibre+OFDM 26.0 Tbit/s** 325 OFDM ch (50 km) IPQ 2011

**Fibre+Nyquist 32.5 Tbit/s** 325 Nyquist ch (227 km) IPQ 2012

**Bible 100 Mbit  $\Rightarrow$  325,000 bibles/s (250,000 full TV)**

J. Leuthold, G. Raybon, Y. Su, R. Essiambre, S. Cabot, J. Jaques, M. Kauer: 40 Gbit/s transmission and cascaded all-optical wavelength conversion over 1 000 000 km. Electron. Lett. vol. 38 no. 15, July 2002

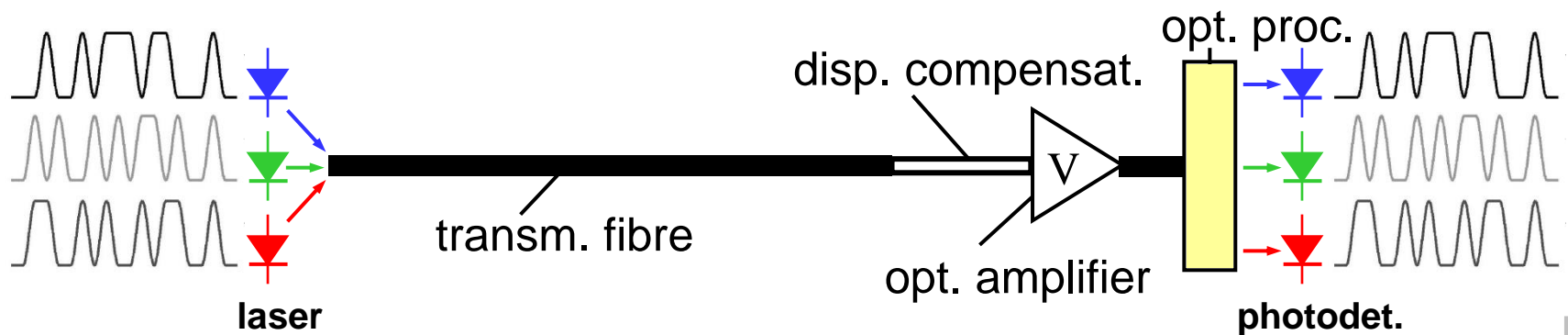
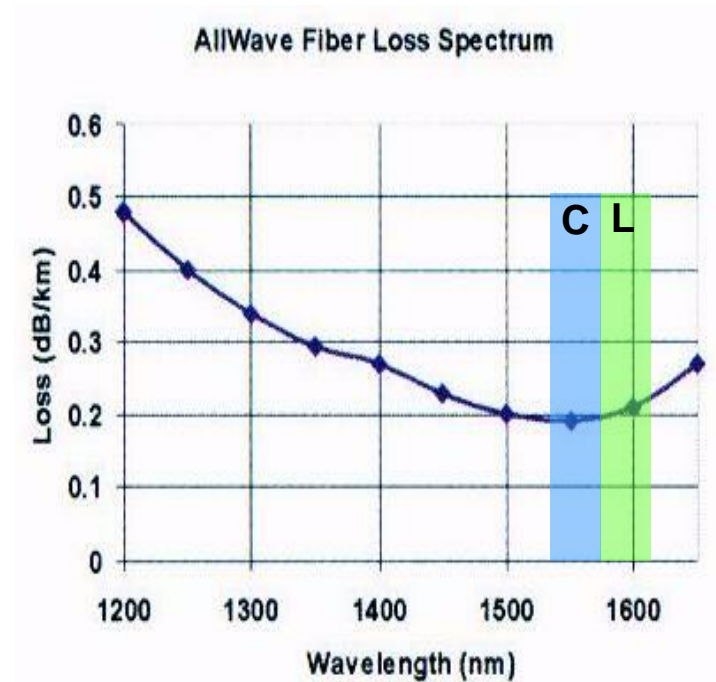
H. G. Weber, S. Ferber, M. Kroh, C. Schmidt-Langhorst, R. Ludwig, V. Marembert, C. Boerner, F. Futami, S. Watanabe, C. Schubert: Single channel 1.28 Tbit/s and 2.56 Tbit/s DQPSK transmission. Electron. Lett. Vol. 42 No. 3, Feb. 2006

H. Masuda, E. Yamazaki, A. Sano, T. Yoshimatsu, T. Kobayashi, E. Yoshida, Y. Miyamoto, S. Matsuoka, Y. Takatori, M. Mizoguchi, K. Okada, K. Hagimoto, T. Yamada, S. Kamei: 13.5-Tb/s (135 x 111-Gb/s/ch) No-guard-interval coherent OFDM transmission over 6,248 km using SNR maximized second-order DRA in the extended L-Band. OFC 2009, PDPB5

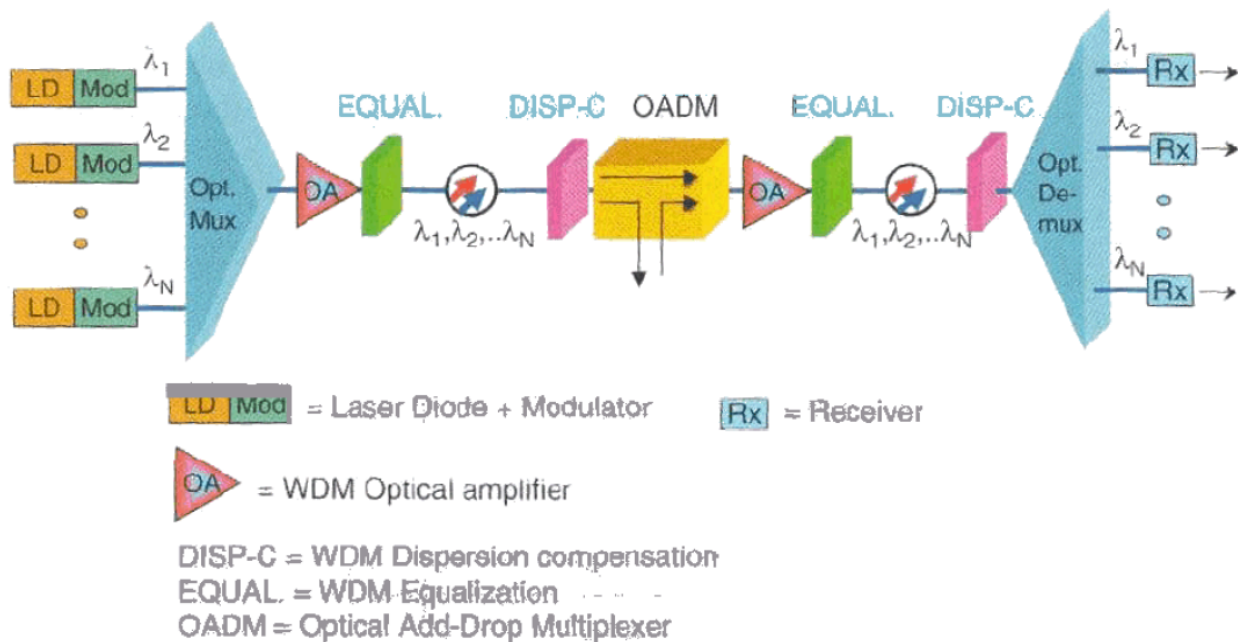


# Optical Wavelength Division Multiplexing (WDM)

- Internet: Need for bandwidth  $B$
- Optical transmission systems
  - fibres:  $B \approx 65$  THz (450 nm)
  - amplifiers:  $B \approx 10$  THz ( 80 nm)
  - wavelength division multiplexing
  - channels:  $\Delta f \approx 5, 10, 25, 50, 100$  GHz
  - capacity:  $40 \text{ Gbit/s} \times 100 \text{ ch} = 4 \text{ Tbit/s}$



# Wavelength Division Multiplexing



**Fig. 1.6.** Wavelength division multiplexing transmission scheme. The path from LD MOD( $\lambda_i$ ) to Rx( $\lambda_i$ ) corresponds to the simplified point-to-point transmission depicted in Fig. 1.1. [after Fig. iii on Page xxiv in reference Footnote 10 on Page 4]



# 12.8Tbit/s Transmission of 160 PDM-QPSK (160x2x40Gbit/s) Channels with Coherent Detection over 2,550km

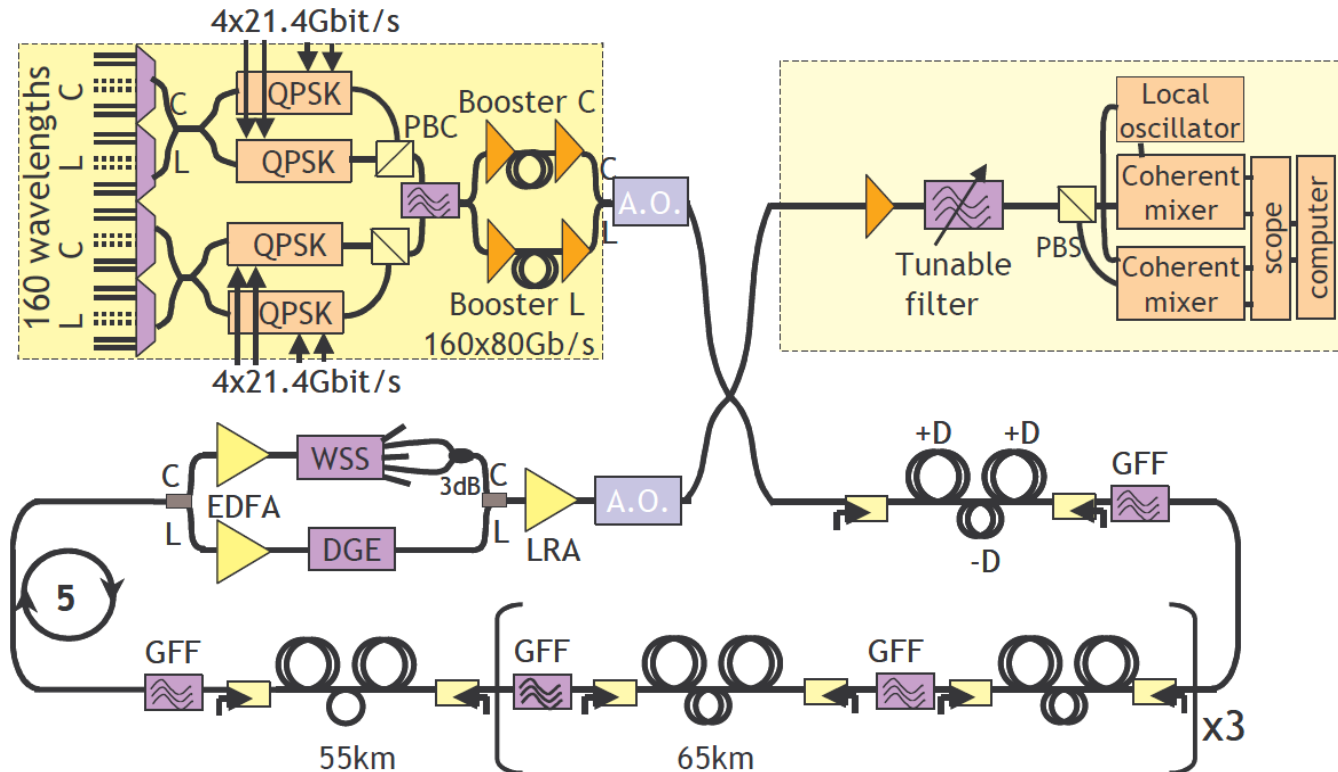
Gabriel Charlet<sup>1</sup>, Jérémie Renaudier<sup>1</sup>, Haik Mardoyan<sup>1</sup>, Oriol Bertran Pardo<sup>1</sup>, Frédéric Céro<sup>2</sup>, Patrice Tran<sup>1</sup>, Sébastien Bigo<sup>1</sup>

1 : Alcatel-Lucent, Research and Innovation, Centre de Villarceaux, 91620, Nozay, France,  
 2 : IRISA/INRIA de Rennes, Campus universitaire de Beaulieu, 35042 Rennes, France

Gabriel.Charlet@alcatel-lucent.fr

## ECOC'07 PDP 1.6

**Abstract:** A 12.8Tbit/s ultra-high capacity transmission is demonstrated over an ultra-long distance of 2,550km thanks to coherent detection and powerful signal processing against chromatic dispersion, PMD and narrow optical filtering.



# 25.6-Tb/s C+L-Band Transmission of Polarization-Multiplexed RZ-DQPSK Signals

A. H. Gnauck<sup>(1)</sup>, G. Charlet<sup>(2)</sup>, P. Tran<sup>(2)</sup>, P. J. Winzer<sup>(1)</sup>, C. R. Doerr<sup>(1)</sup>, J. C. Centanni<sup>(1)</sup>,  
E. C. Burrows<sup>(1)</sup>, T. Kawanishi<sup>(3)</sup>, T. Sakamoto<sup>(3)</sup>, and K. Higuma<sup>(4)</sup>

(1) Alcatel-Lucent, Bell Labs, Holmdel, New Jersey 07733, USA, Email: [gnauck@lucent.com](mailto:gnauck@lucent.com)

(2) Alcatel-Lucent, Research and Innovation, Centre de Villarceaux, Route de Villejust, 91620 NOZAY, France

(3) National Inst. of Information and Communications Technologies (NICT), 4-2-1 Nukui-Kita, Koganei, Tokyo 184-8795, Japan

(4) Sumitomo Osaka Cement, 585 Toyotomi, Funabashi, Chiba 274-8601, Japan

OFC'07 PDP 19

**Abstract:** We demonstrate record 25.6-Tb/s transmission over 240 km using 160 WDM channels on a 50-GHz grid in the C+L bands. Each channel contains two polarization-multiplexed 85.4-Gb/s RZ-DQPSK signals, yielding a spectral efficiency of 3.2 b/s/Hz in each band.

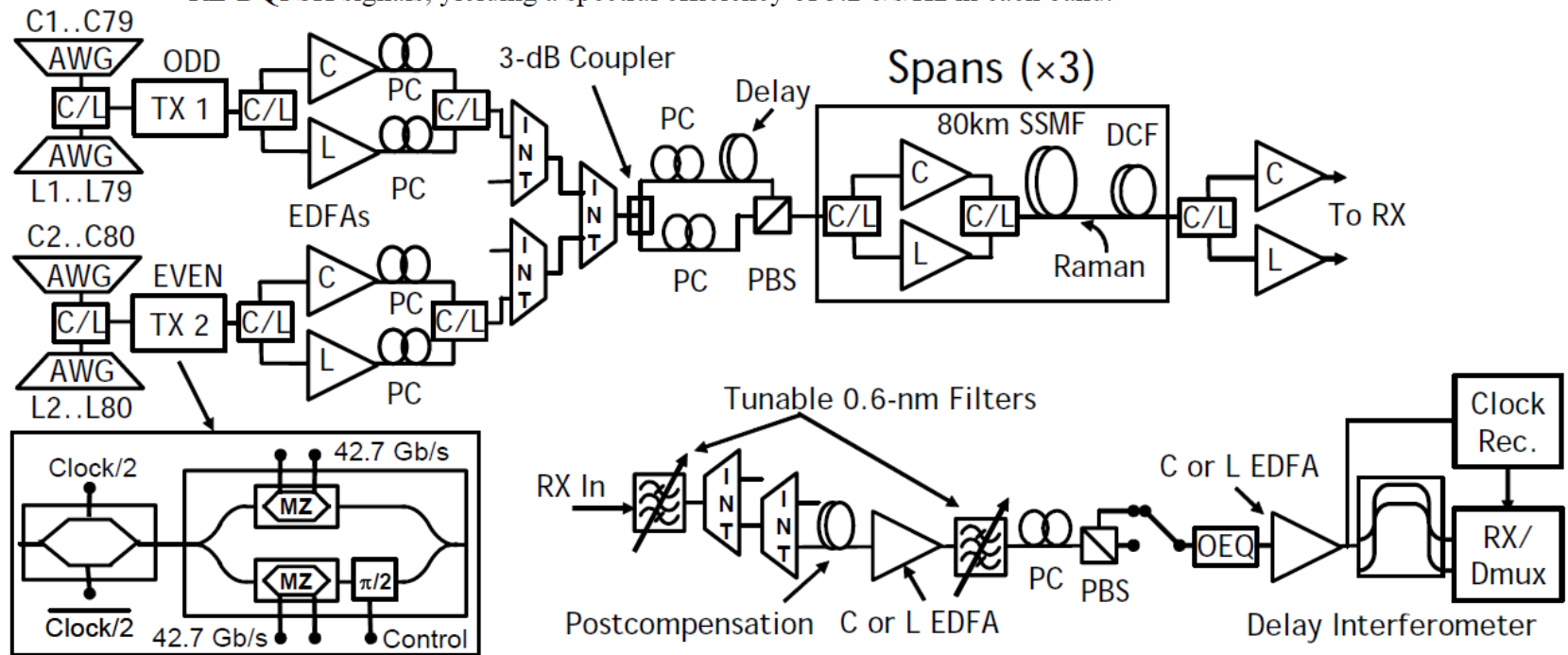


Fig. 1. Experimental setup. AWG: Arrayed Waveguide Grating Router. C/L: C-band/L-band splitter or combiner. INT: 50GHz/100GHz interleaver or de-interleaver. PC: Polarization controller. PBS: Polarization beamsplitter. OEQ: Optical equalizer.





# 32-bit/s/Hz Spectral Efficiency WDM Transmission over 177-km Few-Mode Fiber

R. Ryf<sup>(1)</sup>, S. Randel<sup>(1)</sup>, N. K. Fontaine<sup>(1)</sup>, M. Montoliu<sup>(1,2)</sup>, E. Burrows<sup>(1)</sup>,  
S. Corteselli<sup>(1)</sup>, S. Chandrasekhar<sup>(1)</sup>, A. H. Gnauck<sup>(1)</sup>, C. Xie<sup>(1)</sup>, R.-J. Essiambre<sup>(1)</sup>,  
P. J. Winzer<sup>(1)</sup>, R. Delbue<sup>(3)</sup>, P. Pupalais<sup>(3)</sup>, A. Sureka<sup>(3)</sup>, Y. Sun<sup>(4)</sup>,  
L. Grüner-Nielsen<sup>(5)</sup>, R. V. Jensen<sup>(5)</sup>, and R. Lingle, Jr.<sup>(4)</sup>

<sup>1</sup>Bell Laboratories, Alcatel-Lucent, 791 Holmdel-Keypoint Rd, Holmdel, NJ, 07733, USA.

<sup>2</sup>Universitat Politècnica de Catalunya (ETSETB), Barcelona, Spain

<sup>3</sup>LeCroy Corporation, 700 Chestnut Ridge Road, Chestnut Ridge, NY 10977, USA

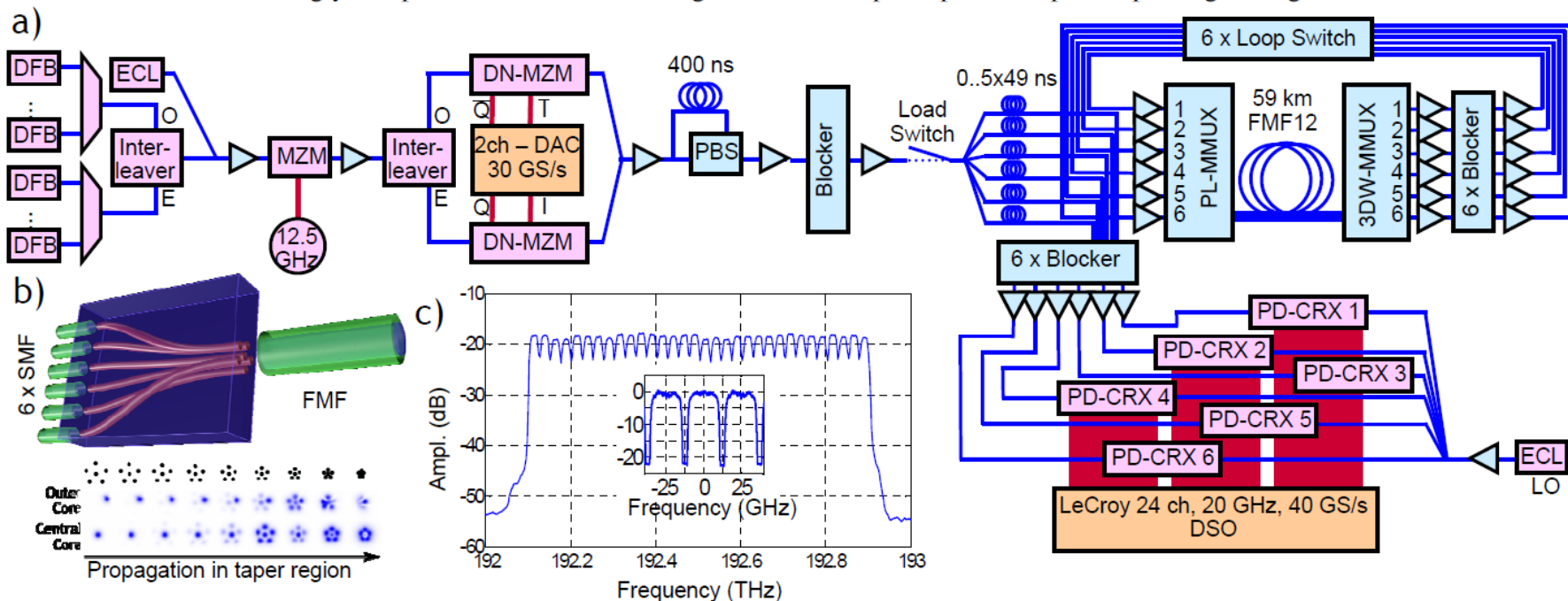
<sup>4</sup>OFS, 2000 Northeast Expressway, Norcross, GA 30071, USA

<sup>5</sup>OFS Fitel Denmark, Priorparken 680, 2605 Brøndby, Denmark.

OFC'13 PDP 5A.1

Roland.Ryf@alcatel-lucent.com

**Abstract:** We transmit 32 WDM channels over 12 spatial and polarization modes of 177 km few-mode fiber at a record spectral efficiency of 32 bit/s/Hz. The transmitted signals are strongly coupled and recovered using 12×12 multiple-input multiple-output digital signal





# Polymer Fibres for In-house Cabling

In future broadband connections become standard:

- Telephone replaced by VoIP (Voice over Internet Protocol)
- Besides TV broadcast, Video/Channel on Demand (IP-TV) becomes important
- Data rates  $\geq 100$  Mbit/s
- Glass fibre closer to the subscriber (VDSL, FTTB, FTTH)
- UMTS-HSxPA, WiMax and satellites fill in the voids

Disadvantages of Cu cables:

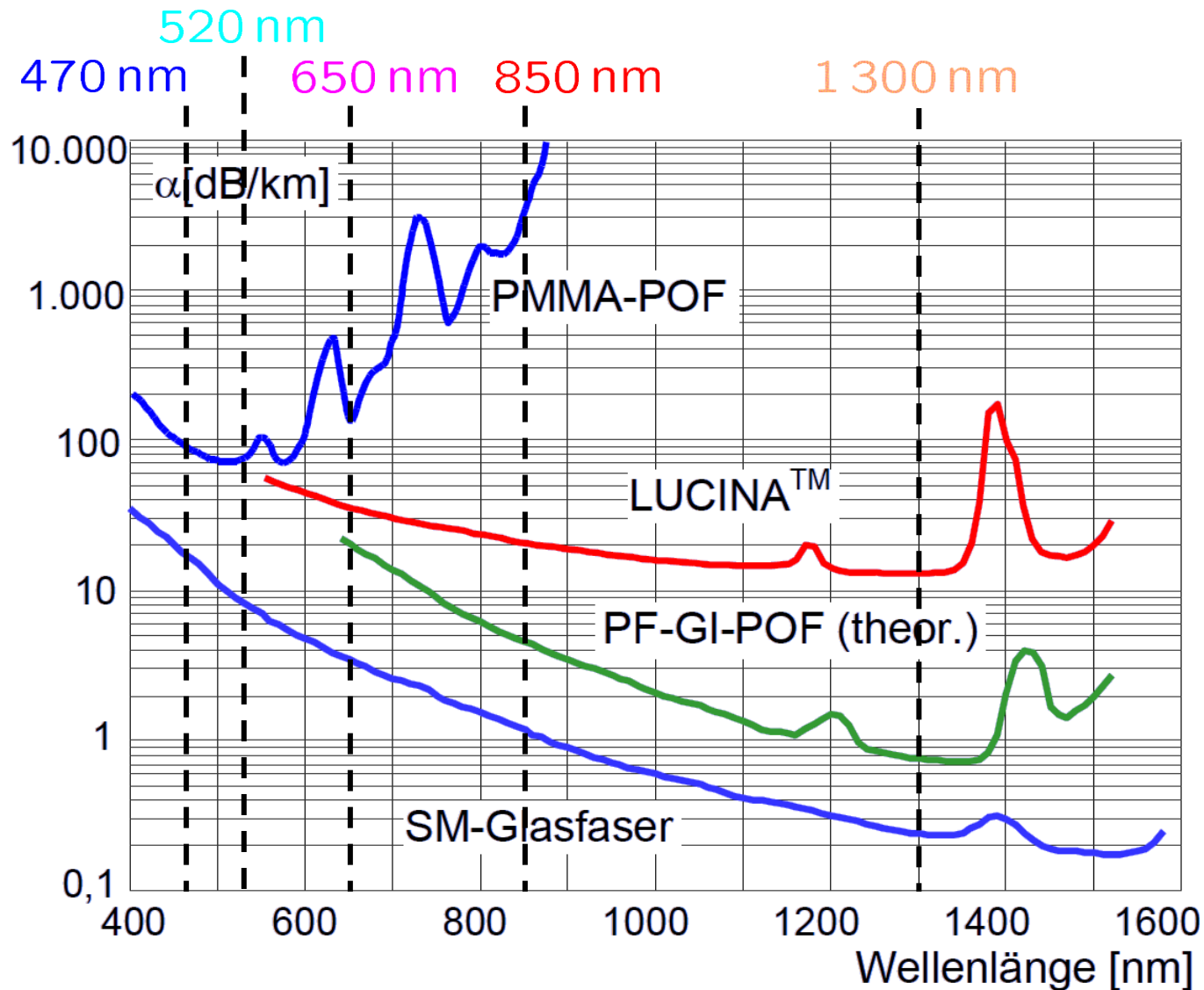
- Cu cables in houses prone to interferences (motors, switched power supplies, computers, starter for gas discharge lamps)
- Many connections only to the building
- New cables require new slots — who pays?

Solution:

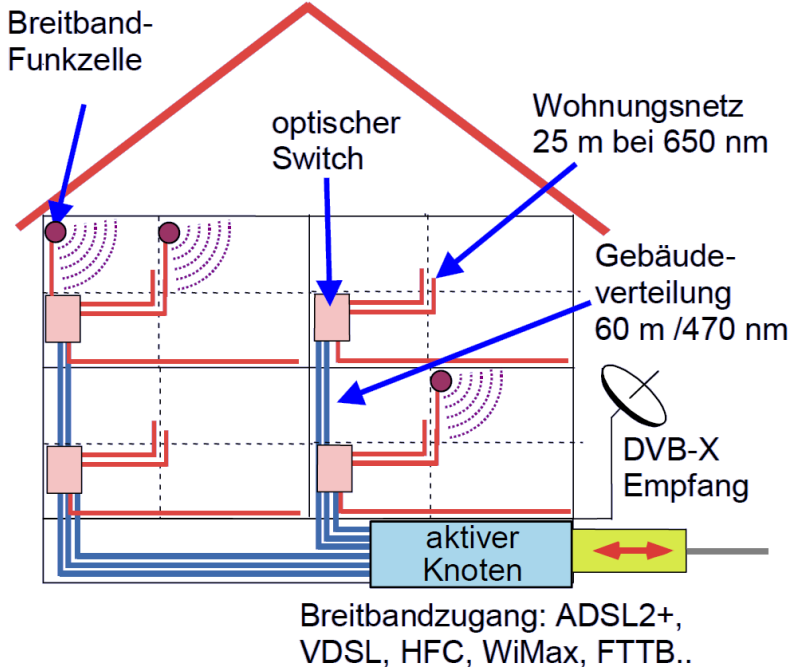
- Plastic optical fibre (POF)



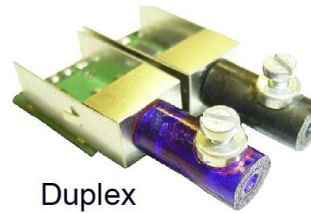
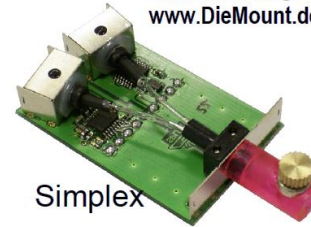
# Attenuation of Glass and Polymer Fibres



# Network Architecture in Buildings Using Multimode Waveguides

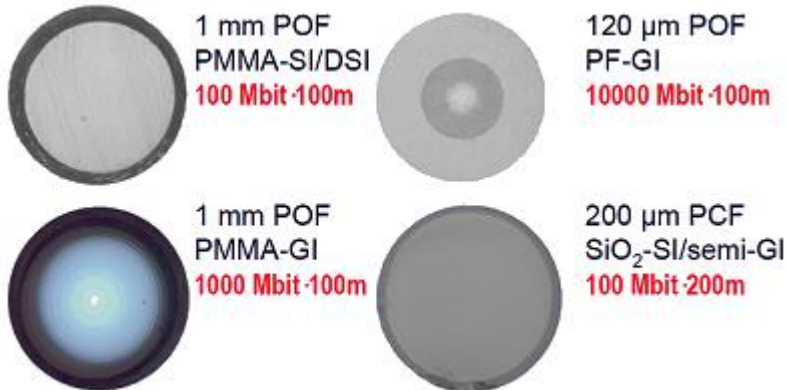
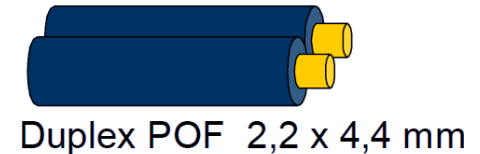
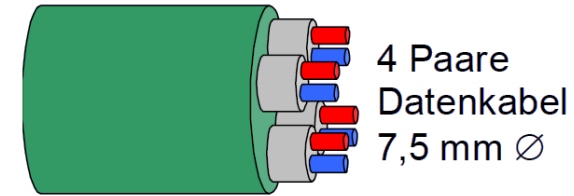
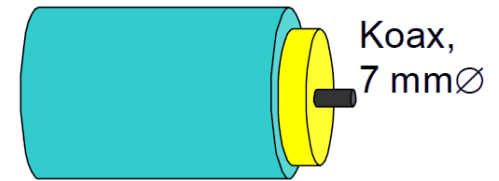


Quelle: H. Kragl  
www.DieMount.de



Ethernet, 1 core,  
red LED,  $\leq 30$  m

Ethernet, 2 cores,  
blue LED,  $\leq 120$  m



Cross-sections  
and cables

<http://www.pofac.de/pofac/de/informationen/downloads.php>



# The Logarithmic Scale

$$\text{dB} = 10 \log_{10} (P_1 / P_0)$$

0 dB	= 1
+ 0.1 dB	= 1.023 (+2.3%)
+ 3 dB	= 2
+ 5 dB	= 3
+ 10 dB	= 10
-3 dB	= 0.5
-10 dB	= 0.1
-20 dB	= 0.01
-30 dB	= 0.001

$$\text{dBm} = 10 \log_{10} (P / 1 \text{ mW})$$

0 dBm	= 1 mW
3 dBm	= 2 mW
5 dBm	= 3 mW
10 dBm	= 10 mW
20 dBm	= 100 mW
-3 dBm	= 0.5 mW
-10 dBm	= 100 $\mu$ W
-30 dBm	= 1 $\mu$ W
-60 dBm	= 1 nW



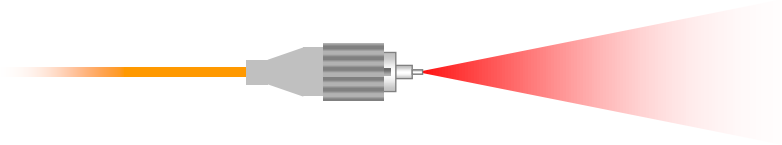
# Optical Power

## Power (P):

- *Transmitter: typ. -6 to +17 dBm (0.25 to 50 mW)*
- *Receiver: typ. -3 to -35 dBm (500 down to 0.3  $\mu$ W)*
- *Optical Amplifier: typ. +3 to +20 dBm (2 to 100 mW)*

## Laser safety

- International standard: IEC 825-1
- United States (FDA): 21 CFR 1040.10
- Both standards consider **class I** safe under reasonable foreseeable conditions of operation (e.g., without using optical instruments, such as lenses or microscopes)



## Why need amplifiers be distributed along a transmission distance?

Due to attenuation in the transmitting fibre the optical signal decays exponentially with the transmission span. Practical spans without amplification are about 70 km. Why are the spans so short?

A transatlantic transmission from New York to London experiences an attenuation of about 1 400 dB (7 000 km @ 0.2 dB / km). Thus, for receiving one photon in London we have to inject  $10^{140}$  photons into the optical fibre end in New York. If all the mass of our sun ( $m_{\text{sun}} = 2 \times 10^{33}$  g) having an energy equivalent of  $W_{\text{sun}} = mc^2 = 1.8 \times 10^{47}$  Ws could be converted into photons with a photon energy  $hf = 6 \times 10^{-34}$  Ws<sup>2</sup>  $\times$  200 THz =  $1.2 \times 10^{-19}$  Ws, we had generated  $1.5 \times 10^{66}$  photons at a wavelength of  $1.55 \mu\text{m}$  ( $f \approx 200$  THz), and could bridge a span with 660 dB loss, corresponding to a transmission distance of 3 300 km only. For a direct transmission New York – London we thus had to evaporate  $10^{140}/10^{66} = 10^{74}$  suns.


Calculations stimulated by an oral presentation of N. J. Doran (S. K. Turitsyn, M. P. Fedoruk, N. J. Doran and W. Forysiak: Optical soliton transmission in fiber lines with short-scale dispersion management. 25th European Conf. on Optical Communication (ECOC'99), Nice, France, September 26–30, 1999)



Why need amplifiers be distributed along a transmission distance?

$10^{74}$  suns are quite a bit. The (observable) universe is estimated to have an extension of  $14 \times 10^9$  light years. Its mean density is supposed to be  $3 \times 10^{-30} \text{ g / cm}^3$

(<http://curious.astro.cornell.edu/question.php?number=342>).

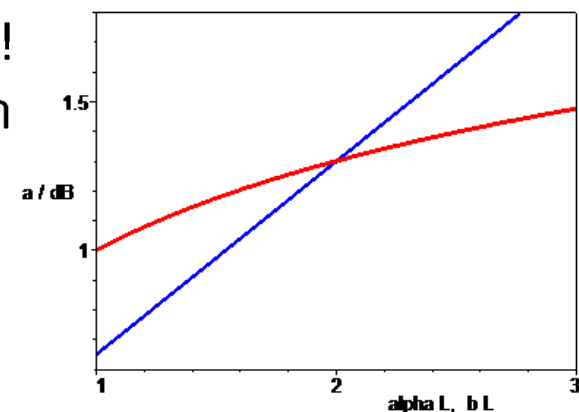
So, the universe's mass (comprising not only suns) is  $m_{\text{univ}} = 7 \times 10^{54} \text{ g}$ , and its energy equivalent is  $W_{\text{univ}} = m_{\text{univ}}c^2 = 6 \times 10^{68} \text{ Js}$  corresponding to  $4.7 \times 10^{87}$  photons at a wavelength of  $1.55 \mu\text{m}$ . If we are able to receive one photon then the maximum span will be  $877 \text{ dB} / (0.2 \text{ dB / km}) = 4385 \text{ km}$ . 

However, for bridging the distance New York – London in one go we had to burn  $10^{140} / 10^{87} = 10^{53}$  universes!

How come — NY supernova not visible in London? Spherical  $\sim (bL)^2$ , fibre  $\sim \exp(\alpha L)$ :

$$a_{\text{free space}} / \text{dB} \sim 10 \lg \left[ (bL)^2 \right] = 20 \lg (bL)$$

$$a_{\text{fibre}} / \text{dB} = 10 \lg \left[ \exp(\alpha L) \right] = 4.34(\alpha L)$$



Universe's mass calculations and web address contributed by Dipl.-Phys. Jan Brückner, DFG Research Training Group 786 "Mixed Fields and Nonlinear Interactions" (<http://www.gkmf.uni-karlsruhe.de>), Karlsruhe, Germany, June 23, 2005

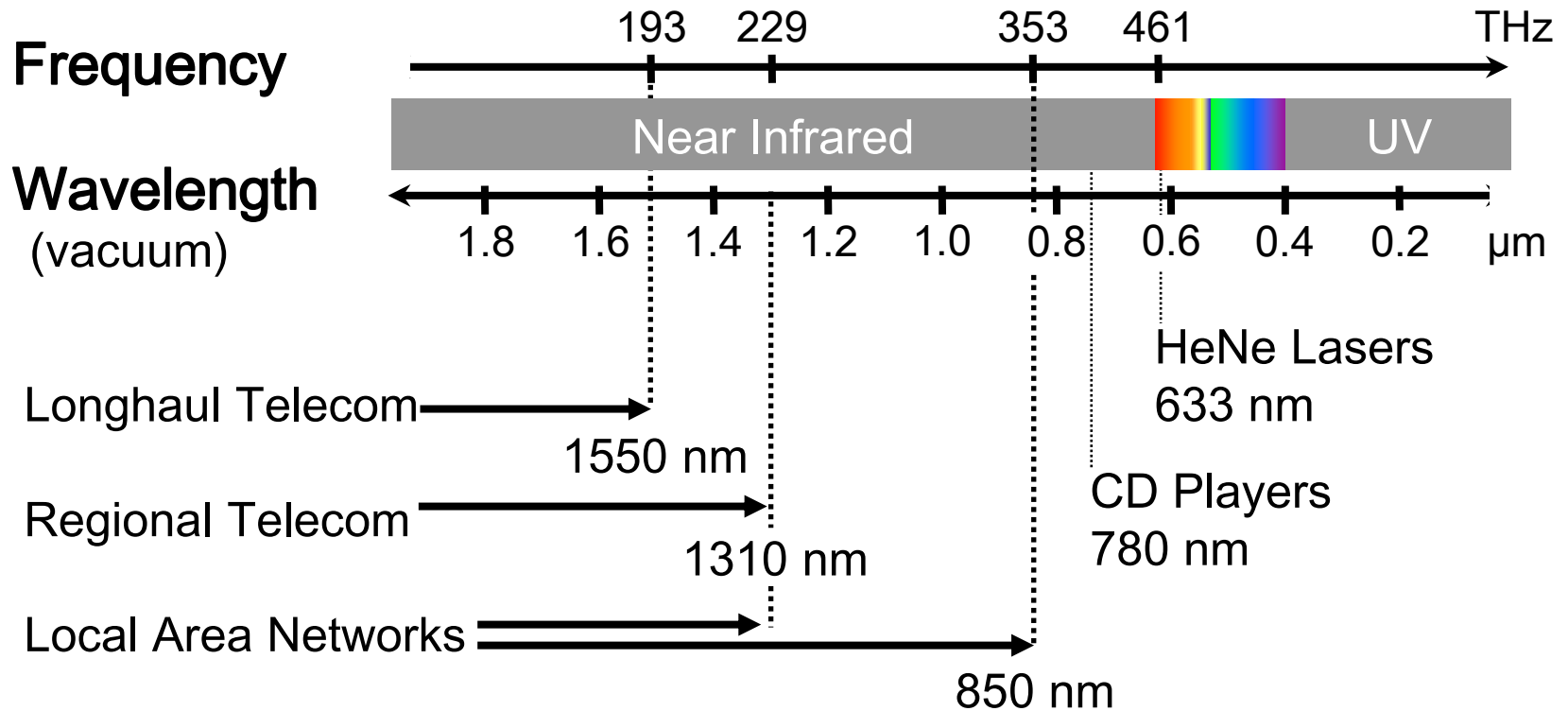


# LECTURE 2

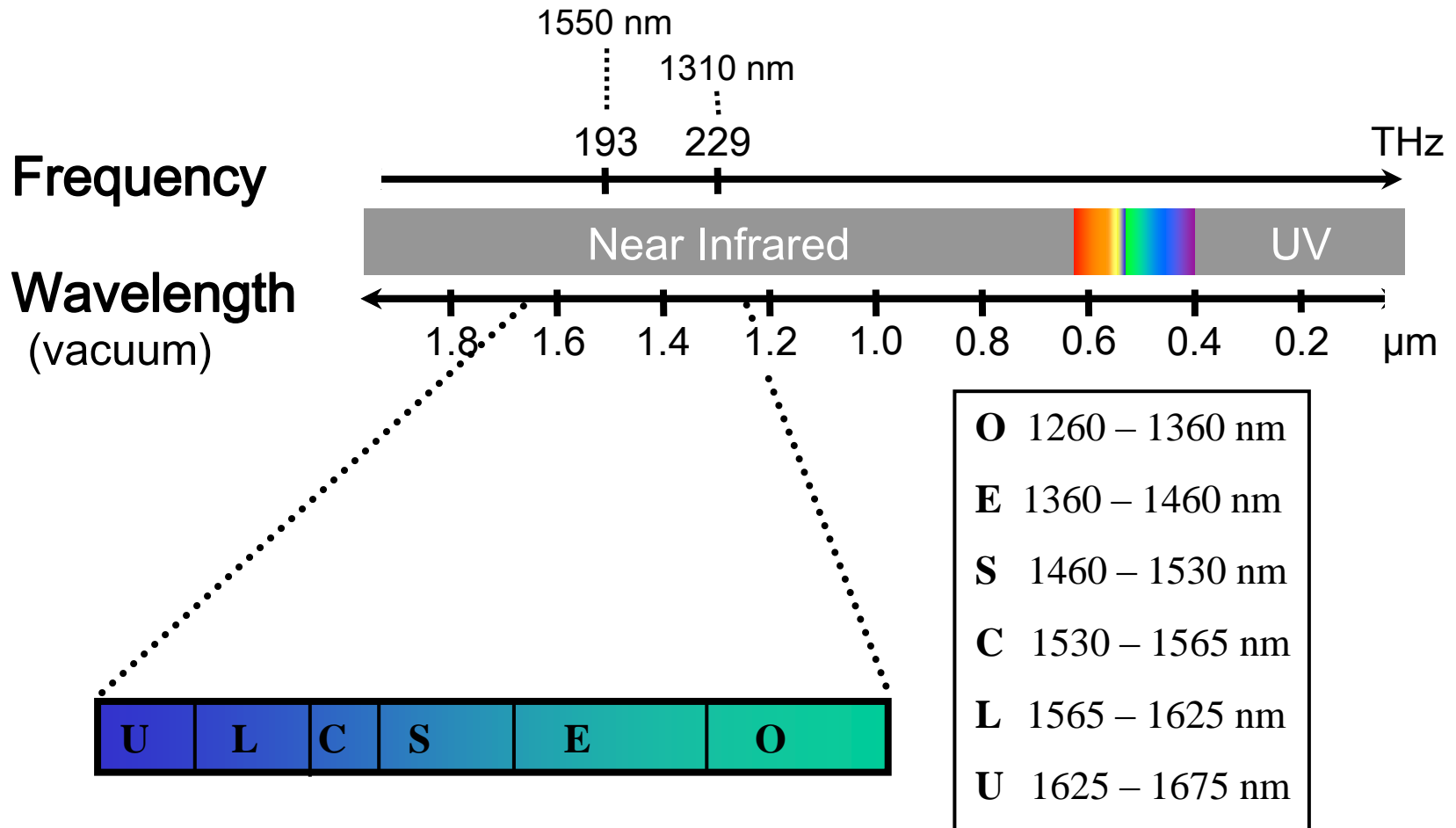




# LW Transmission Bands



# LW Transmission Bands - ITU Proposed Assignment



# Transmission Bands

Designation of 40-nm bands ( $\lambda/\mu\text{m}$ ) at $\lambda = 1.550\mu\text{m}$										
S+		S		C		L		L+		
1.450	<b>1.470</b>	1.490	<b>1.510</b>	1.530	<b>1.550</b>	1.570	<b>1.590</b>	1.610	<b>1.630</b>	1.650

**Table 1.1.** Designation of bands at  $\lambda = 1.550\mu\text{m}$

Wavelength table for the C-band (DWDM ITU-T grid)					
$\lambda_{\text{ITU}}/\text{nm}$	$\lambda_{\text{ITU}}/\text{nm}$	$\lambda_{\text{ITU}}/\text{nm}$	$\lambda_{\text{ITU}}/\text{nm}$	$\lambda_{\text{ITU}}/\text{nm}$	$\lambda_{\text{ITU}}/\text{nm}$
1 527.99	1 534.25	1 540.56	1 546.92	1 553.33	1 559.78
1 528.77	1 535.04	1 541.35	1 547.72	1 554.13	1 560.61
1 529.55	1 535.82	1 542.14	1 548.51	1 554.94	1 561.42
1 530.33	1 536.61	1 542.94	1 549.32	1 555.75	1 562.23
1 531.12	1 537.40	1 543.73	1 550.12	1 556.55	1 563.05
1 531.90	1 538.19	1 544.53	1 550.92	1 557.36	$\Delta = 0.79$
1 532.68	1 538.98	1 545.32	1 551.72	1 558.17	<b>all:</b>
1 533.47	1 539.77	1 546.12	1 552.52	1 558.98	<b><math>\pm 0.1</math></b>

**Table 1.2.** DWDM ITU-T grid at  $\lambda = 1.550\mu\text{m}$ . Channel spacing corresponds to frequency grid  $\Delta f = 100\text{GHz}$



# Standard ITU Channel Grid

CH	Frequency(THz)	Wavelength(nm)	CH	Frequency(THz)	Wavelength(nm)
15	191.500	1,565.4961	44	194.400	1,542.1425
16	191.600	1,564.6790	45	194.500	1,541.3496
17	191.700	1,563.8628	46	194.600	1,540.5576
18	191.800	1,563.0475	47	194.700	1,539.7663
19	191.900	1,562.2329	48	194.800	1,538.9759
20	192.000	1,561.4193	49	194.900	1,538.1863
21	192.100	1,560.6065	50	195.000	1,537.3974
22	192.200	1,559.7945	51	195.100	1,536.6094
23	192.300	1,558.9834	52	195.200	1,535.8222
24	192.400	1,558.1731	53	195.300	1,535.0358
25	192.500	1,557.3636	54	195.400	1,534.2503
26	192.600	1,556.5550	55	195.500	1,533.4655
27	192.700	1,555.7473	56	195.600	1,532.6815
28	192.800	1,554.9404	57	195.700	1,531.8983
29	192.900	1,554.1343	58	195.800	1,531.1159
30	193.000	1,553.3290	59	195.900	1,530.3344
31	193.100	1,552.5246	60	196.000	1,529.5536
32	193.200	1,551.7210	61	196.100	1,528.7736
33	193.300	1,550.9183	62	196.200	1,527.9944
34	193.400	1,550.1163	63	196.300	1,527.2160
35	193.500	1,549.3153	64	196.400	1,526.4384
36	193.600	1,548.5150	65	196.500	1,525.6616
37	193.700	1,547.7155	66	196.600	1,524.8856
38	193.800	1,546.9169	67	196.700	1,524.1103
39	193.900	1,546.1191	68	196.800	1,523.3359
40	194.000	1,545.3222	69	196.900	1,522.5622
41	194.100	1,544.5260	70	197.000	1,521.7893
42	194.200	1,543.7307	71	197.100	1,521.0200
43	194.300	1,542.9362	72	197.200	1,520.2500

**Reference frequency: 195 THz**

**Basic grid:**

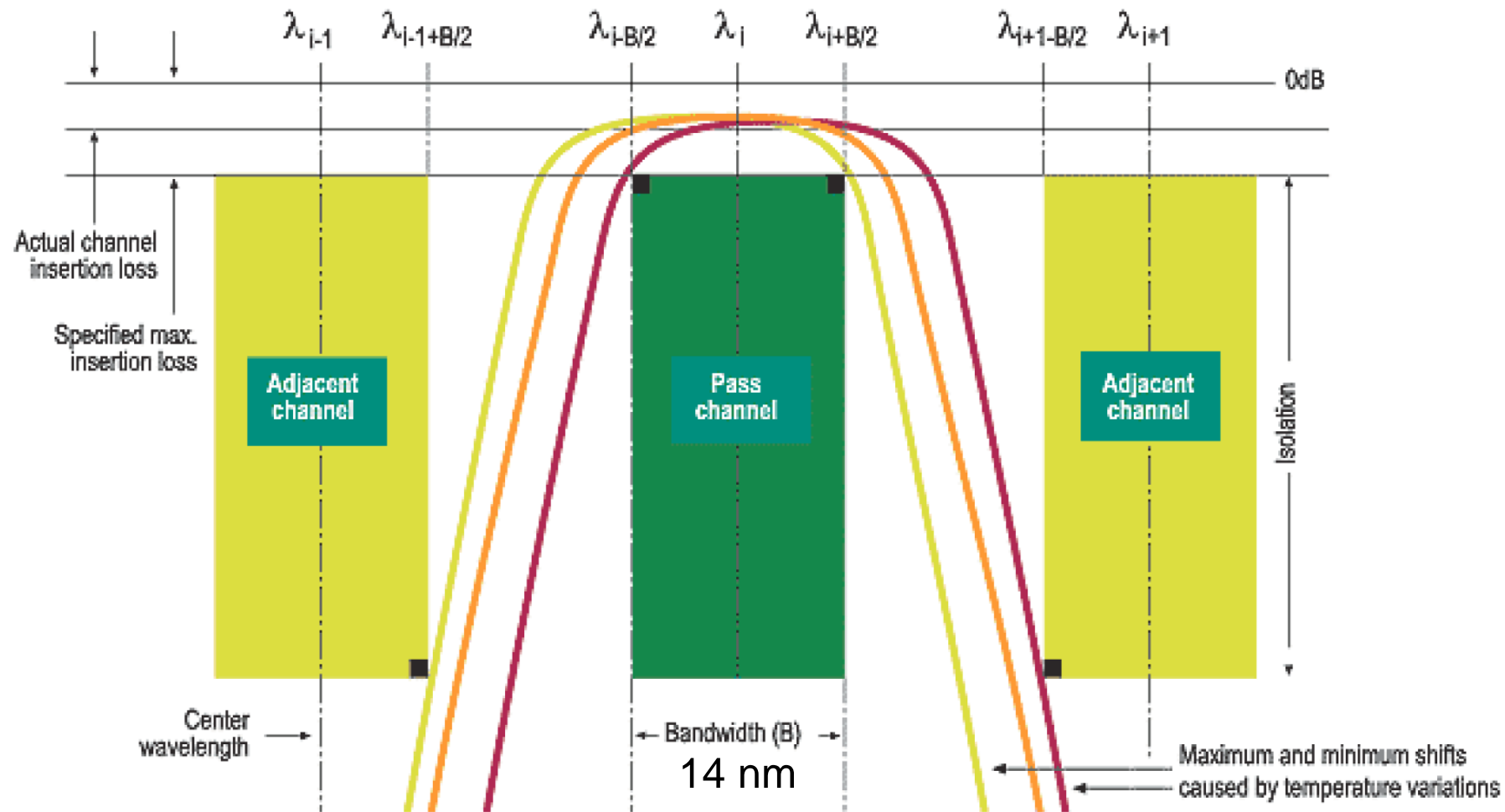
**100 GHz ( $\approx 0.79$  nm)**

**Subdivisions:**

**50 GHz or 25 GHz**



# CWDM Channel Grid



Coarse wavelength division multiplexing: Channel grid with  $\Delta\lambda = 20 \text{ nm}$ , i.e., filter allows  $\pm 6.7 \text{ nm}$  laser drift (thermal/aging), guard band width is  $6.7 \text{ nm}$ .



# Advantages of Optical Communications

- Large transmission capacity because of the large fibre bandwidth in the order of  $(250 \dots 190) \text{ THz} = 60 \text{ THz}$
- Low fibre loss, about 2.2, 0.35, 0.15 dB/km at  $\lambda = 0.85, 1.3, 1.55 \mu\text{m}$ , i. e., down to 3 dB loss for a fibre length of  $L = 20 \text{ km}$  corresponding to a power attenuation by a factor of only 2
- Immunity to interference because of the high carrier frequency, and because of the strong confinement of the light inside the fibre

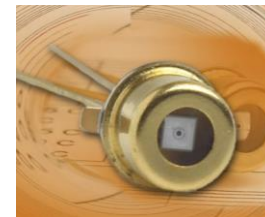
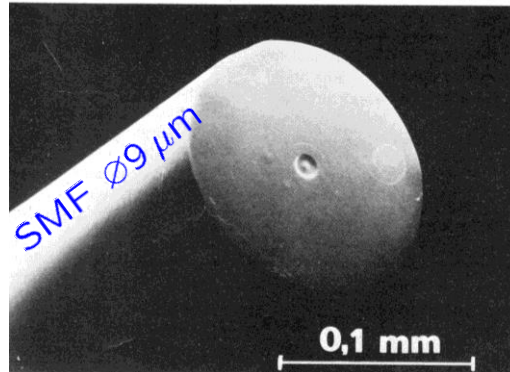
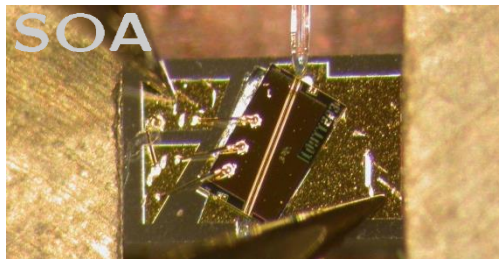
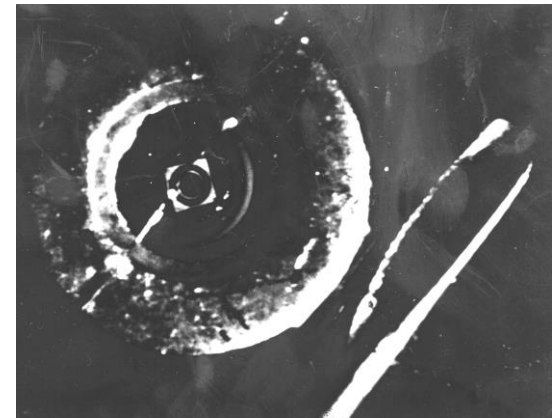
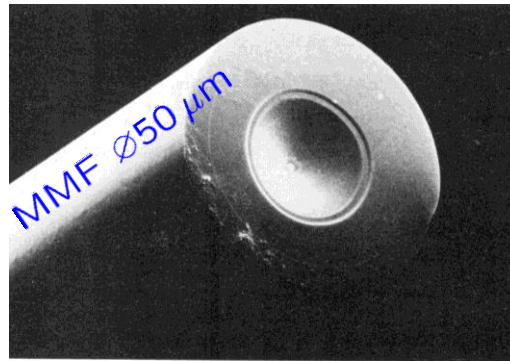
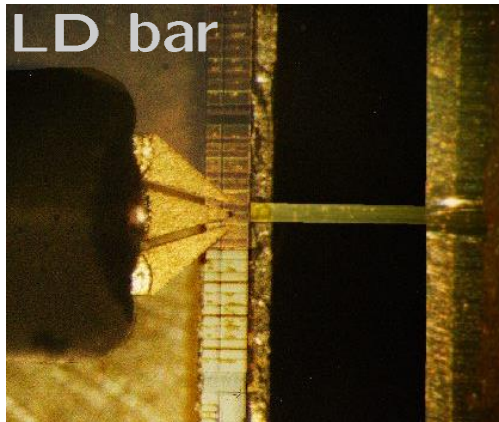
## Organization of Course

1. Introduction
  2. Light Waveguides
  3. Light sources
  4. Optical amplifiers
  5. Pin photodiode
  6. Noise
  7. Receivers and detection errors
- Summaries, problems and quizzes**

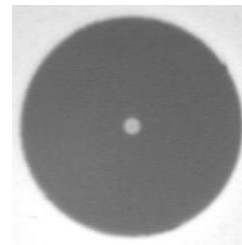
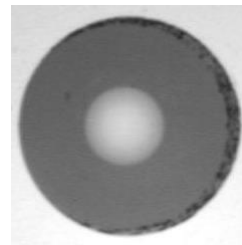


# Photonics: Basic Components

Probe, laser bar, fibre — glass fibres — photodiode, eye of a needle



Multimode fibre  
 $2a = 65 \mu\text{m}$



Single-mode fibre  
 $2a = 9 \mu\text{m}$



# LECTURE 3





# Fundamentals of Wave Propagation

## Maxwell's Equations

$$\begin{aligned}\operatorname{curl} \vec{H} &= \frac{\partial \vec{D}}{\partial t}, & \operatorname{curl} \vec{E} &= -\frac{\partial \vec{B}}{\partial t}, \\ \operatorname{div} \vec{D} &= 0, & \operatorname{div} \vec{B} &= 0, \\ \vec{D} &= \epsilon_0 \vec{E} + \vec{P}, & \vec{B} &= \mu_0 \vec{H}\end{aligned}$$

## Fourier Transform

$$\Psi(t) = \int_{-\infty}^{+\infty} \bar{\Psi}(f) e^{+j2\pi ft} df, \quad \bar{\Psi}(f) = \int_{-\infty}^{+\infty} \Psi(t) e^{-j2\pi ft} dt$$



# Medium Properties

$$\vec{P}(t, \vec{r}) = \epsilon_0 \int_0^{\infty} \chi_t(\tau, \vec{r}) \vec{E}(t - \tau, \vec{r}) d\tau,$$

$$\vec{P}(f) = \epsilon_0 \underline{\chi}(f) \vec{E}(f), \quad \underline{\chi}(f) = \int_0^{\infty} \chi_t(t) e^{-j2\pi ft} dt,$$

$$\underline{\chi}(f) = \chi(f) + j\chi_i(f) = \epsilon_r(f) - 1 - j\epsilon_{ri}(f), \quad \underline{\chi}(f) = \underline{\chi}^*(-f)$$

## Refractive Index and Dielectric Constant $\bar{\epsilon}_r = \bar{n}^2$

$$\begin{aligned} \bar{n} &= n - jn_i, & \bar{\epsilon}_r &= \epsilon_r - j\epsilon_{ri}, \\ \epsilon_r &= n^2 - n_i^2, & \epsilon_{ri} &= 2nn_i, \\ n^2 &= \frac{1}{2}\epsilon_r \left( 1 + \sqrt{1 + \epsilon_{ri}^2/\epsilon_r^2} \right), & n_i &= \epsilon_{ri}/(2n), \\ n &\approx \sqrt{\epsilon_r} & n_i &\approx \epsilon_{ri}/(2\sqrt{\epsilon_r}), \\ n &\approx \sqrt{|\epsilon_{ri}|}/2 & n_i &\approx \text{sgn}(\epsilon_{ri})\sqrt{|\epsilon_{ri}|}/2 \end{aligned}$$

(for  $|\epsilon_{ri}| \ll \epsilon_r$ )                      (for  $|\epsilon_{ri}| \gg \epsilon_r$ )



# Causal Time Functions and Analytic Spectra

**Because of causality:** Real and imaginary parts interconnected by so-called Hilbert transform and its inverse,  $\bar{\Psi} = \mathcal{H}_F\{\bar{\Psi}_i\}$  and  $\bar{\Psi}_i = \mathcal{H}_F^{-1}\{\bar{\Psi}\}$ :

$$\bar{\Psi}_i(f_0) = \frac{1}{\pi} \mathcal{P} \int_{-\infty}^{+\infty} \frac{\bar{\Psi}(f)}{f - f_0} df, \quad \bar{\Psi}(f_0) = -\frac{1}{\pi} \mathcal{P} \int_{-\infty}^{+\infty} \frac{\bar{\Psi}_i(f)}{f - f_0} df$$

**Cauchy's principle value integral** ( $\mathcal{P}$  means 'valor principalis', Latin for principle value) is defined for a general function  $f(x)$  by:

$$\mathcal{P} \int_{-\infty}^{+\infty} \frac{f(x)}{x - x_0} dx = \lim_{\varepsilon \rightarrow 0} \left( \int_{-\infty}^{x_0 - \varepsilon} \frac{f(x)}{x - x_0} dx + \int_{x_0 + \varepsilon}^{+\infty} \frac{f(x)}{x - x_0} dx \right)$$



# Kramers-Kronig Relation

$$\underbrace{-\epsilon_{ri}(f)}_{\Im\{\chi(f)\}} = \frac{1}{\pi} \mathcal{P} \int_{-\infty}^{+\infty} \frac{\epsilon_r(f') - 1}{f' - f} df', \quad \underbrace{\epsilon_r(f) - 1}_{\Re\{\chi(f)\}} = \frac{1}{\pi} \mathcal{P} \int_{-\infty}^{+\infty} \frac{\epsilon_{ri}(f')}{f' - f} df'$$



For  $\chi(f) = \epsilon_r(f) - 1 = \text{const}_f$ :  $\epsilon_{ri}(f) = 0$  (anti-symmetric denominator in RHS integral) and therefore  $\epsilon_r(f) = 1$  and  $\chi(t) = 0$ , i. e., no memory, no medium, no polarization. Real media with memory, so  $\chi, \chi_i$  are always frequency dependent.

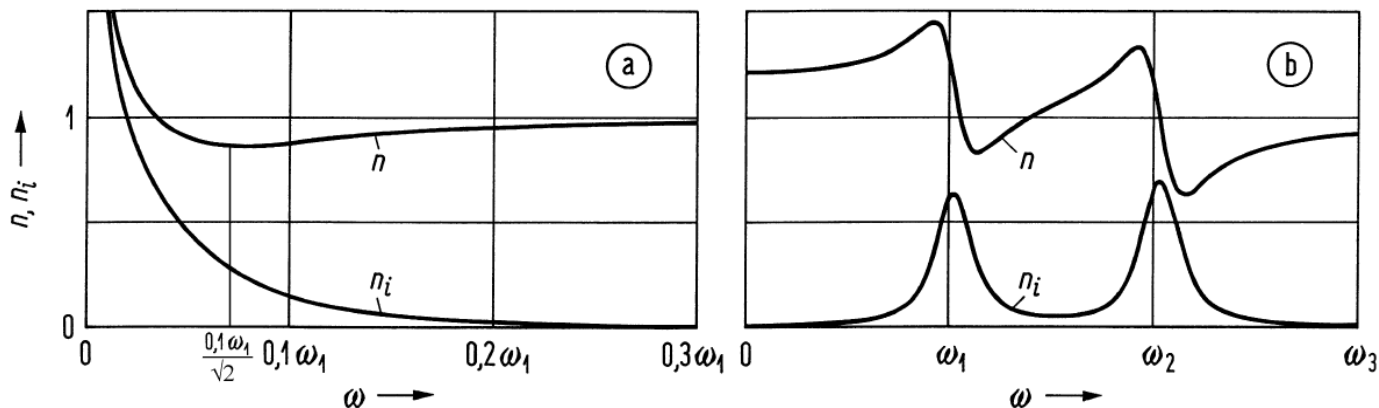
In certain frequency ranges possible:  $\chi = \text{const}$  and  $\chi_i = 0$ . Then: Medium with real and constant refractive index. That this holds true for all frequencies (valid only for vacuum!) is implicitly assumed in the usual ansatz for  $\vec{D}(t)$ ,

$$\vec{D} = \epsilon_0 \epsilon_r \vec{E}, \quad n = \sqrt{\epsilon_r}$$





# Free and Bound Charge Carriers



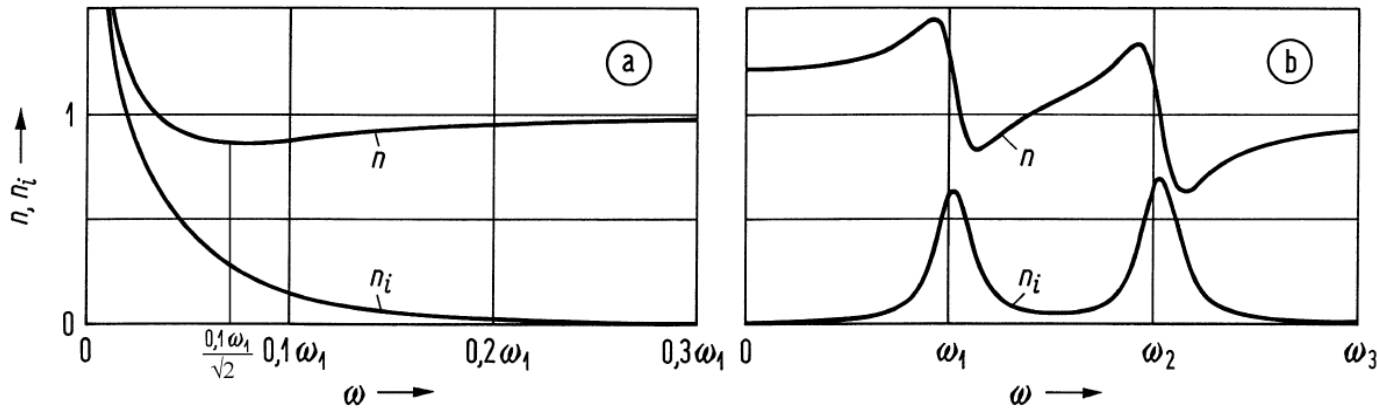
**Fig. 2.1.** Real part  $n$  and negative imaginary part ( $n_i$ ) of complex refractive index  $\bar{n} = n - j n_i$ : Frequency dependence (a) Free carriers only (b) Two collectives of bound charges with high mass (ions, low angular resonance frequency  $\omega_1$ ) and low mass (electrons, high angular resonance frequency  $\omega_2$ )

$\vec{E}$ -field forces atoms of molecules and bound electrons to vibrate. Force  $\vec{F}$  exerted on charge  $q$  is  $\vec{F} = q\vec{E}$ . Assuming  $\vec{E} = E_x \vec{e}_x$  and neglecting losses  $\rightarrow$  Newton's second law: sum of forces (driving plus restoring force, proportionality constant  $\omega_r^2$ ) equals mass  $m_r$  times acceleration  $\rightarrow$  electric dipole moment  $P_x = qN x$ ,  $a = \hat{a} e^{j\omega t}$ :

$$qE_x(t) - m_r\omega_r^2 x(t) = m_r \frac{d^2 x(t)}{dt^2}, \quad \hat{x}(f) = \frac{q/m_r}{\omega_r^2 - \omega^2} \hat{E}_x(f) = \frac{\hat{P}_x(f)}{qN}$$



# Free and Bound Charge Carriers



**Fig. 2.1.** Real part  $n$  and negative imaginary part ( $n_i$ ) of complex refractive index  $\bar{n} = n - j n_i$ : Frequency dependence (a) Free carriers only (b) Two collectives of bound charges with high mass (ions, low angular resonance frequency  $\omega_1$ ) and low mass (electrons, high angular resonance frequency  $\omega_2$ )

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$$\hat{P}_x(f) = \frac{q^2 N / m_r}{\omega_r^2 - \omega^2} \hat{E}_x(f), \quad \vec{D} = \epsilon_0 \epsilon_r \vec{E} = \epsilon_0 \vec{E} + \vec{P} = \epsilon_0 \left( 1 + \frac{q^2 N / (\epsilon_0 m_r)}{\omega_r^2 - \omega^2} \right) \vec{E}$$



# Plasma Oscillation

$\vec{E}$ -field forces free electrons to vibrate, no restoring force,  $\omega_r = 0$ .  
 Electron displacement  $\vec{x} \sim -q\vec{E}$  opposite to driving force  $\vec{F} = q\vec{E}$   
 (no loss:  $180^\circ$  out of phase at all frequencies  $\omega \neq 0$ ).

Free electrons oscillating out of phase with incident light re-radiate wavelets that tend to cancel the incoming disturbance  $\rightarrow$  rapidly decaying refracted wave.

Spatially fixed positive ions with concentration  $N$  providing  $f_e$  free electrons each, which produce polarization (relative diel. const.  $\epsilon_r$ , refract. index  $n$ , imag. part  $-n_i$ , real  $\bar{\epsilon}_r = n^2 - n_i^2$ ,  $\epsilon_{ri} = 2nn_i = 0$ ):

$$\vec{P} = -eN f_e \frac{-e/m_e}{-\omega^2} \vec{E} = -\frac{N f_e e^2}{m_e \omega^2} \vec{E}, \quad \vec{D} = \epsilon_0 \epsilon_r \vec{E} = \epsilon_0 \vec{E} + \vec{P},$$

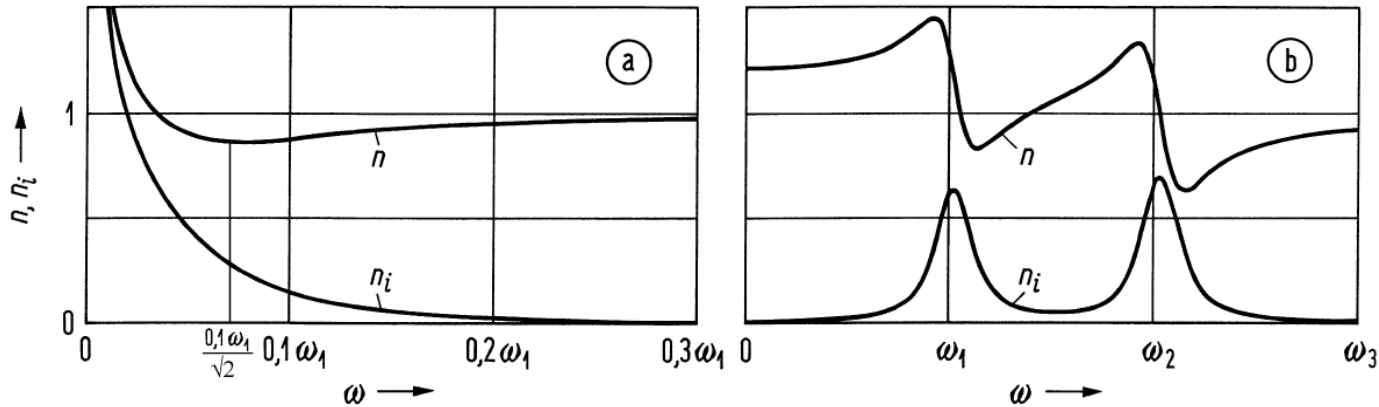
$$\bar{\epsilon}_r = \bar{n}^2 = 1 - \frac{N f_e e^2}{\epsilon_0 m_e \omega^2} = 1 - \frac{\omega_p^2}{\omega^2}, \quad \omega_p^2 = \frac{N f_e e^2}{\epsilon_0 m_e}$$

if  $\bar{\epsilon}_r > 0$ :  $n_i = 0$   
 if  $\bar{\epsilon}_r < 0$ :  $n = 0$

Fig. 2.1a: Plasma (ang.) frequency  $\omega_p = \frac{0.1\omega_1}{\sqrt{2}} \approx 0.7071 \times (0.1\omega_1)$



# Free and Bound Charge Carriers



**Fig. 2.1.** Real part  $n$  and negative imaginary part ( $n_i$ ) of complex refractive index  $\bar{n} = n - j n_i$ : Frequency dependence (a) Free carriers only (b) Two collectives of bound charges with high mass (ions, low angular resonance frequency  $\omega_1$ ) and low mass (electrons, high angular resonance frequency  $\omega_2$ )

$$\frac{dn}{d\omega} > 0, \quad \frac{dn}{d\lambda} < 0 \quad \text{normal dispersion}$$

$$\frac{dn}{d\omega} < 0, \quad \frac{dn}{d\lambda} > 0 \quad \text{anomalous dispersion}$$





# Homogeneous Medium — Monochromatic Waves

## Maxwell's Equations

$$\begin{aligned}\operatorname{curl} \vec{H} &= \frac{\partial \vec{D}}{\partial t}, & \operatorname{curl} \vec{E} &= -\frac{\partial \vec{B}}{\partial t}, \\ \operatorname{div} \vec{D} &= 0, & \operatorname{div} \vec{B} &= 0, \\ \vec{D} &= \epsilon_0 \epsilon_r \vec{E}, & \vec{B} &= \mu_0 \vec{H}\end{aligned}$$

For Cartesian coordinates only:

$$\Psi(t, x, y, z) = E_q(t, x, y, z), H_q(t, x, y, z), \quad q = x, y, z,$$

$$\Psi(t, r, \varphi, z) = E_z(t, r, \varphi, z), H_z(t, r, \varphi, z),$$

$$\nabla^2 \Psi(t, \vec{r}) = \frac{n^2}{c^2} \frac{\partial^2}{\partial t^2} \Psi(t, \vec{r})$$



Decoupled versions of Maxwell's equations, starting with:

$$\text{curl } \vec{H} = \epsilon_0 \epsilon_r \frac{\partial}{\partial t} \vec{E}, \quad \text{curl } \vec{E} = -\mu_0 \frac{\partial}{\partial t} \vec{H},$$

$$\text{curl curl } \vec{H} = \epsilon_0 \epsilon_r \frac{\partial}{\partial t} \text{curl } \vec{E} + \text{grad}(\epsilon_0 \epsilon_r) \times \frac{\partial}{\partial t} \vec{E}, \quad \text{curl curl } \vec{E} = -\mu_0 \frac{\partial}{\partial t} \text{curl } \vec{H}$$

Further:

$$\begin{aligned} \text{div } \vec{H} &= 0, \\ \text{div}(\epsilon_0 \epsilon_r \vec{E}) &= \epsilon_0 \epsilon_r \text{div } \vec{E} + \text{grad}(\epsilon_0 \epsilon_r) \cdot \vec{E} = 0, \\ \text{div } \vec{E} &= -\frac{\text{grad}(\epsilon_0 \epsilon_r) \cdot \vec{E}}{\epsilon_0 \epsilon_r} = -\text{grad} \ln(\epsilon_r) \cdot \vec{E} \end{aligned}$$

With the help of the vector identity:

$$\nabla^2 \vec{E} = \text{grad div } \vec{E} - \text{curl curl } \vec{E}, \quad \Delta \Psi = \text{div grad } \Psi$$

(differential operator  $\nabla^2$  operates on vector  $\vec{E}$ , not identical with Laplace operator  $\Delta$  as applied to scalar function  $\Psi$ )  $\rightarrow$  Decoupled relations:

$$\begin{aligned} \nabla^2 \vec{H} &= \text{grad div } \vec{H} - \text{curl curl } \vec{H} = -\epsilon_0 \epsilon_r \frac{\partial}{\partial t} \text{curl } \vec{E} - \text{grad}(\epsilon_0 \epsilon_r) \times \frac{\partial}{\partial t} \vec{E} \\ &= -\epsilon_0 \epsilon_r \frac{\partial}{\partial t} \left( -\mu_0 \frac{\partial}{\partial t} \vec{H} \right) - \text{grad}(\epsilon_0 \epsilon_r) \times \frac{1}{\epsilon_0 \epsilon_r} \text{curl } \vec{H}, \end{aligned}$$

$$\begin{aligned} \nabla^2 \vec{E} &= \text{grad div } \vec{E} - \text{curl curl } \vec{E} = \text{grad} \left( -\text{grad} \ln(\epsilon_r) \cdot \vec{E} \right) - \left( -\mu_0 \frac{\partial}{\partial t} \text{curl } \vec{H} \right) \\ &= \text{grad} \left( -\text{grad} \ln(\epsilon_r) \cdot \vec{E} \right) - \left( -\mu_0 \frac{\partial}{\partial t} \left( \epsilon_0 \epsilon_r \frac{\partial}{\partial t} \vec{E} \right) \right) \end{aligned}$$



## Decoupled Versions of Maxwell's Equations (2)

Decoupled relations:

$$\begin{aligned}\nabla^2 \vec{H} &= \text{grad div } \vec{H} - \text{curl curl } \vec{H} = -\epsilon_0 \epsilon_r \frac{\partial}{\partial t} \text{curl } \vec{E} - \text{grad}(\epsilon_0 \epsilon_r) \times \frac{\partial}{\partial t} \vec{E} \\ &= -\epsilon_0 \epsilon_r \frac{\partial}{\partial t} \left( -\mu_0 \frac{\partial}{\partial t} \vec{H} \right) - \text{grad}(\epsilon_0 \epsilon_r) \times \frac{1}{\epsilon_0 \epsilon_r} \text{curl } \vec{H},\end{aligned}$$

$$\begin{aligned}\nabla^2 \vec{E} &= \text{grad div } \vec{E} - \text{curl curl } \vec{E} = \text{grad} \left( -\text{grad ln}(\epsilon_r) \cdot \vec{E} \right) - \left( -\mu_0 \frac{\partial}{\partial t} \text{curl } \vec{H} \right) \\ &= \text{grad} \left( -\text{grad ln}(\epsilon_r) \cdot \vec{E} \right) - \left( -\mu_0 \frac{\partial}{\partial t} \left( \epsilon_0 \epsilon_r \frac{\partial}{\partial t} \vec{E} \right) \right)\end{aligned}$$

Simplification yields ( $c^2 = (\mu_0 \epsilon_0)^{-1}$ ):

$$\nabla^2 \vec{H} + \text{grad ln}(\epsilon_r) \times \text{curl } \vec{H} = \frac{\epsilon_r}{c^2} \frac{\partial^2 \vec{H}}{\partial t^2},$$

$$\nabla^2 \vec{E} + \text{grad} \left( \text{grad ln}(\epsilon_r) \cdot \vec{E} \right) = \frac{\epsilon_r}{c^2} \frac{\partial^2 \vec{E}}{\partial t^2} \quad \blacksquare$$



# Homogeneous Medium — Monochromatic Waves

$$\nabla^2 \vec{E} + \text{grad} \left( (\text{grad} \ln n^2) \cdot \vec{E} \right) = \frac{n^2}{c^2} \frac{\partial^2 \vec{E}}{\partial t^2},$$
$$\nabla^2 \vec{H} + (\text{grad} \ln n^2) \times \text{curl} \vec{H} = \frac{n^2}{c^2} \frac{\partial^2 \vec{H}}{\partial t^2}$$

$$\begin{aligned} \nabla^2 \vec{E} &= \text{grad} \text{div} \vec{E} - \text{curl} \text{curl} \vec{E} = \\ &= \vec{e}_x \text{div} \text{grad} E_x + \vec{e}_y \text{div} \text{grad} E_y + \vec{e}_z \text{div} \text{grad} E_z = \\ &= \vec{e}_x \nabla^2 E_x + \vec{e}_y \nabla^2 E_y + \vec{e}_z \nabla^2 E_z = \vec{e}_x \Delta E_x + \vec{e}_y \Delta E_y + \vec{e}_z \Delta E_z \end{aligned}$$

For Cartesian coordinates only:

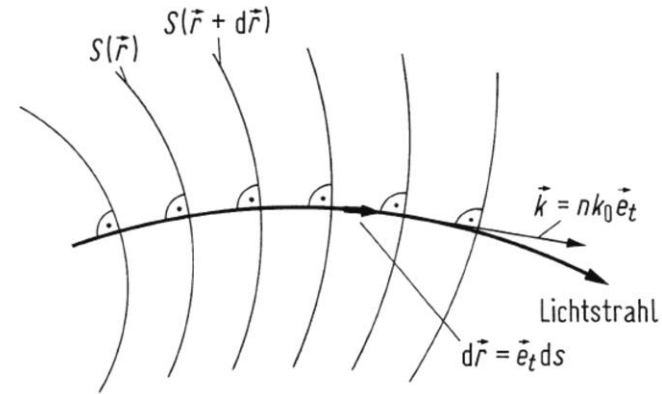
$$\Psi(t, x, y, z) = E_q(t, x, y, z), H_q(t, x, y, z), \quad q = x, y, z,$$

$$\Psi(t, r, \varphi, z) = E_z(t, r, \varphi, z), H_z(t, r, \varphi, z),$$

$$\nabla^2 \Psi(t, \vec{r}) = \frac{n^2}{c^2} \frac{\partial^2}{\partial t^2} \Psi(t, \vec{r})$$



# Amplitude and Phase Surfaces



Monochromatic wave ( $A, \varphi, \varphi_i$  real):

$$\Psi(t, \vec{r}) = A(\vec{r}) e^{j[\omega t - \varphi(\vec{r})]} = e^{j\omega t} e^{-j\bar{\varphi}(\vec{r})},$$

$$\bar{\varphi}(\vec{r}) = \varphi(\vec{r}) + j\varphi_i(\vec{r})$$

$A(\vec{r})$  and  $\varphi(\vec{r})$ : Amplitude and phase of wave

$A(\vec{r}) = \text{const}$ : Ampl. surface ( $\varphi_i(\vec{r}) = \text{const}$ )

$\varphi(\vec{r}) = \text{const}$ : Phase surface

Amplitude vector:  $\vec{a} = -\text{grad } \varphi_i$

Phase vector:  $\vec{b} = \text{grad } \varphi$

Propagation vector:  $\text{grad } \bar{\varphi}$  (real  $\vec{a}, \vec{b}$ )

$$\text{grad } \bar{\varphi} = \text{grad } \varphi + j \text{grad } \varphi_i = \vec{b} - j\vec{a}$$





# Plane Waves in a Homogeneous Medium

Wave equation in homogeneous medium:

$$\nabla^2 \Psi(t, \vec{r}) \equiv \left( \frac{\partial^2}{\partial x^2} + \frac{\partial^2}{\partial y^2} + \frac{\partial^2}{\partial z^2} \right) \Psi(t, \vec{r}) = \frac{n^2}{c^2} \frac{\partial^2}{\partial t^2} \Psi(t, \vec{r})$$

With separation ansatz for plane phase fronts:

$$\begin{aligned} \Psi(t, \vec{r}) &= \exp(j\omega t) \exp[-j\bar{\varphi}(\vec{r})] \\ &= \exp(j\omega t) \exp(-j\vec{k} \cdot \vec{r}) = \exp(j\omega t) \exp[-j(k_x x + k_y y + k_z z)] \end{aligned}$$

Valid for separation condition:

$$\begin{aligned} (-k_x^2 - k_y^2 - k_z^2) \Psi(t, \vec{r}) &= -\omega^2 \frac{n^2}{c^2} \Psi(t, \vec{r}), \\ k_x^2 + k_y^2 + k_z^2 &\stackrel{!}{=} n^2 \left( \frac{\omega}{c} \right)^2 = n^2 k_0^2 \end{aligned}$$

Separation condition leads to separation constant  $nk_0$ , thus:

$$\bar{\varphi}(\vec{r}) = \vec{k} \cdot \vec{r}, \quad \vec{k}^2 = \vec{k} \cdot \vec{k} = n^2 k_0^2 \quad (\text{real!}), \quad k_0 = \frac{\omega}{c} = 2\pi \frac{f}{c} = \frac{2\pi}{\lambda}$$



# Phase Velocity and Plane Waves

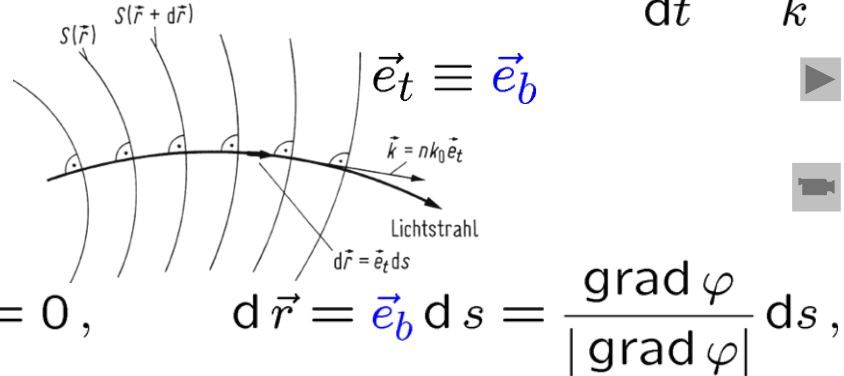
**Velocity of phase surface** (phase front) in direction of propagation defines phase velocity  $v$  of wave. In 1D version,  $\exp [j (\omega t - kz)]$  with total phase  $\phi = \omega t - kz$  and  $d\phi = 0$ :

$$d\phi = d(\omega t) - d(kz) = \frac{\partial (\omega t)}{\partial t} dt - \frac{\partial (kz)}{\partial z} dz = \omega dt - k dz = 0 \rightarrow v = \frac{dz}{dt} = \frac{\omega}{k}$$

**Vectorial notation**,  $\exp [j (\omega t - \varphi(\vec{r}))]$ :

$$\omega dt - d\varphi(\vec{r}) = \omega dt - \frac{\partial \varphi(\vec{r})}{\partial \vec{r}} \cdot d\vec{r}$$

$$= \omega dt - \text{grad } \varphi \cdot d\vec{r} = 0,$$



$$\omega dt = \frac{(\text{grad } \varphi) \cdot (\text{grad } \varphi)}{|\text{grad } \varphi|} ds = \frac{|\text{grad } \varphi|^2}{|\text{grad } \varphi|} ds \rightarrow v = \frac{ds}{dt} = \frac{\omega}{|\text{grad } \varphi|} = \frac{\omega}{|\vec{b}|}$$

**Propagation along  $\vec{b}$**  normal to phase surfaces. Unit vector  $\vec{e}_b = \vec{b}/|\vec{b}| = \text{grad } \varphi/|\text{grad } \varphi|$  ( $\equiv \vec{e}_t$  tangential to  $\vec{r}$ ) with phase velocity  $v$ .

**Waves named after shape of phase surfaces.**



# Homogeneous Plane Waves — Phase and Group Velocity

**Phase velocity**  $v$  for homogeneous plane waves defined formerly.  
Additionally: Group velocity  $v_g$ , **group delay**  $t_g$  for geometrical propagation length  $L$ , propagation constant  $k$ :

$$v = \frac{\omega}{k} = \frac{c}{n}, \quad v_g = \frac{d\omega}{dk} = \frac{c}{n_g}, \quad n_g = n + f \frac{dn}{df} = n - \lambda \frac{dn}{d\lambda},$$
$$k = n \frac{\omega}{c}, \quad \frac{t_g}{L} = \frac{dk}{d\omega} = \frac{n_g}{c}, \quad \frac{dn_g}{d\lambda} = -\lambda \frac{d^2 n}{d\lambda^2}.$$

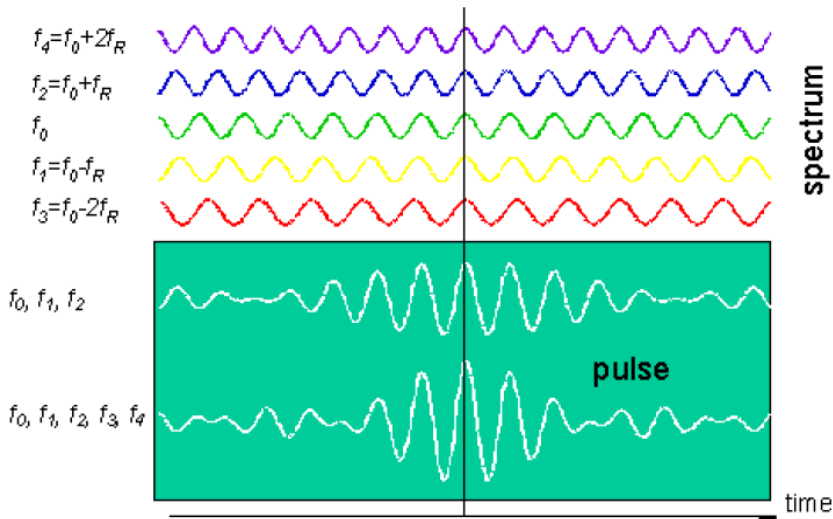
The **group refractive index**  $n_g$  represents an effective refractive index for the propagation of a wave group in a dispersive medium, its derivative measures the group delay difference.



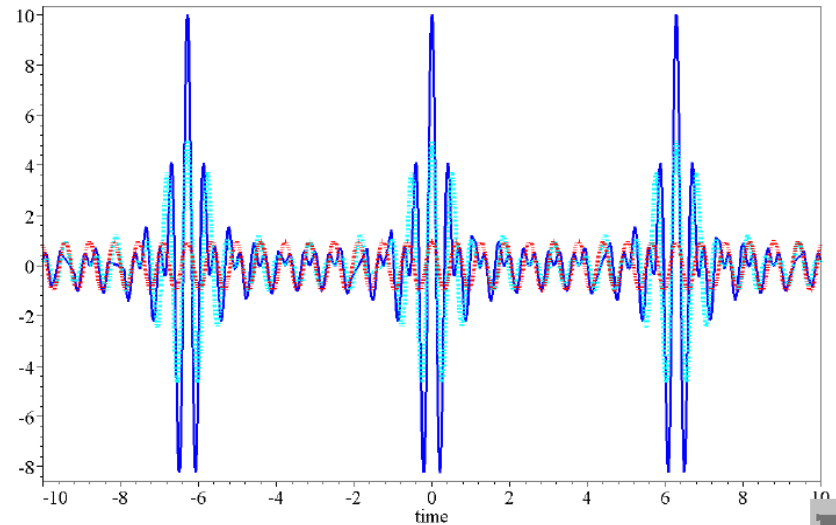
# LECTURE 4



# Group Velocity — Physical Meaning



(a) Superposition of three and five sinusoids



(b) Superposition of one, five and ten sinusoids

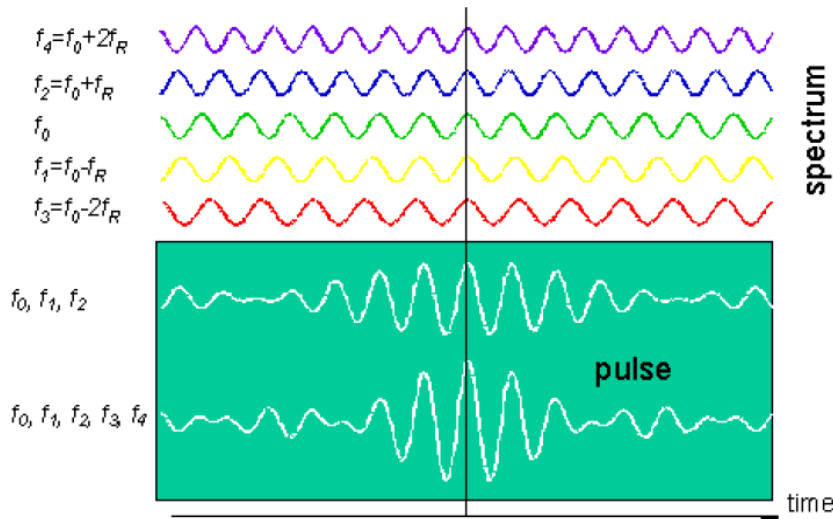
Signal localized in time, superposition of  $n$  sinusoids with equidistant frequencies. (a)  $N = 3, 5$  for a limited time span (b)  $N = 1, 5, 10$  for a more extended time span. If the frequency increment  $f_R \rightarrow 0$  decreases and the number of sinusoidal  $N \rightarrow \infty$  increases, the peaks become narrower and their time distance in (b) approaches infinity, so that a single Dirac impulse  $\delta(t)$  remains.

**How do we transport information?** The answer is, by signals localized in time. Why so? We need to be taken by surprise. Information theory says that the less predictable an event is, the more information it carries.

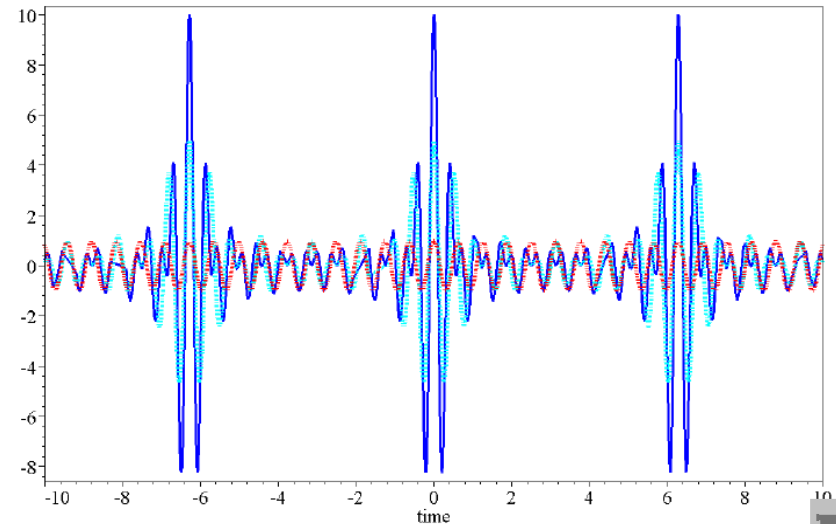




# Localization in Time



(a) Superposition of three and five sinusoids



(b) Superposition of one, five and ten sinusoids

But: A superposition of sinusoids with different frequencies is localized in time!  $N = 2$  homogeneous plane waves,

$$\begin{aligned} \psi(t, z) &= \cos(\omega_1 t - k_1 z) + \cos(\omega_2 t - k_2 z) \\ &= 2 \cos\left(\frac{\omega_1 - \omega_2}{2} t - \frac{k_1 - k_2}{2} z\right) \cos\left(\frac{\omega_1 + \omega_2}{2} t - \frac{k_1 + k_2}{2} z\right) \\ v_g &= \frac{\Delta\omega}{\Delta k} = \frac{c}{n_g}, & v &= \frac{\omega}{k} = \frac{c}{n} \end{aligned}$$



# More on Adding Phasors with Equidistant Frequencies

Sum of periodic functions is periodic:

$$\sum_{i=0}^{N-1} \cos(\omega_0 + i\omega_R)t = \frac{\sin(N\omega_R t/2)}{\sin(\omega_R t/2)} \cos\left(\omega_0 + \frac{N-1}{2}\omega_R\right)t$$

For  $\omega_0 = 0$ ,  $\omega_R \rightarrow 0$ ,  $N \rightarrow \infty$ ,  $N\omega_R = \text{const}$ ,

$\cos(x - y) = \cos x \cos y + \sin x \sin y$ ,  $\sin x \cos x = \frac{1}{2} \sin(2x)$ , and

$$\cos(\omega t) = \frac{e^{-j2\pi f t} + e^{j2\pi f t}}{2},$$

$$\int_{-Nf_R}^{+Nf_R} \sin(\omega t) df = 0 :$$

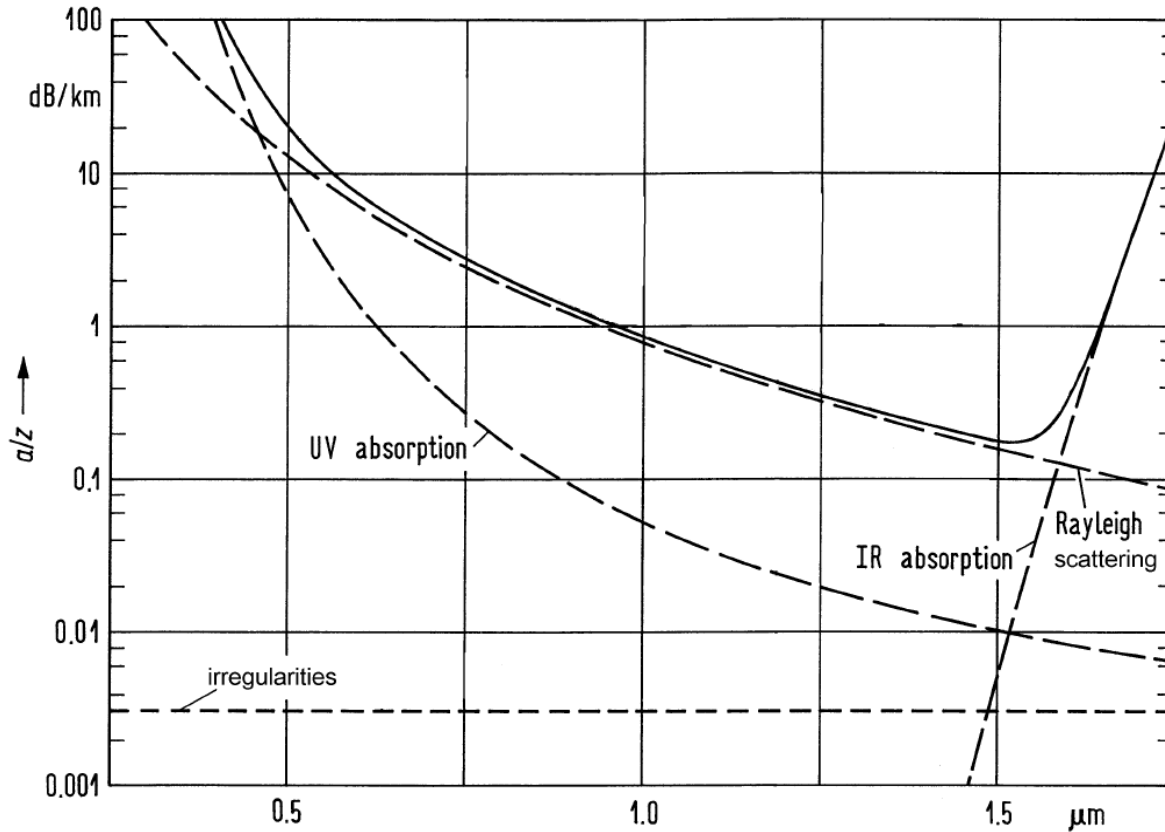
$$\lim_{\substack{\omega_R \rightarrow 0 \\ N \rightarrow \infty \\ N\omega_R = \text{const}}} \frac{\omega_R}{\pi} \sum_{i=0}^{N-1} \cos(i\omega_R t) = \frac{N\omega_R}{\pi} \frac{\sin(N\omega_R t)}{N\omega_R t} \quad \text{non-per./periodic!}$$

$$\lim_{N\omega_R \rightarrow \infty} \frac{N\omega_R}{\pi} \frac{\sin(N\omega_R t)}{N\omega_R t} = \lim_{Nf_R \rightarrow \infty} \int_{-Nf_R}^{+Nf_R} \cos(\omega t) df$$

$$\text{non-periodic!} = \lim_{Nf_R \rightarrow \infty} \int_{-Nf_R}^{+Nf_R} e^{-j2\pi f t} df = \delta(t)$$



# Properties of Silica Glass — Attenuation



Losses through scattering and absorption.

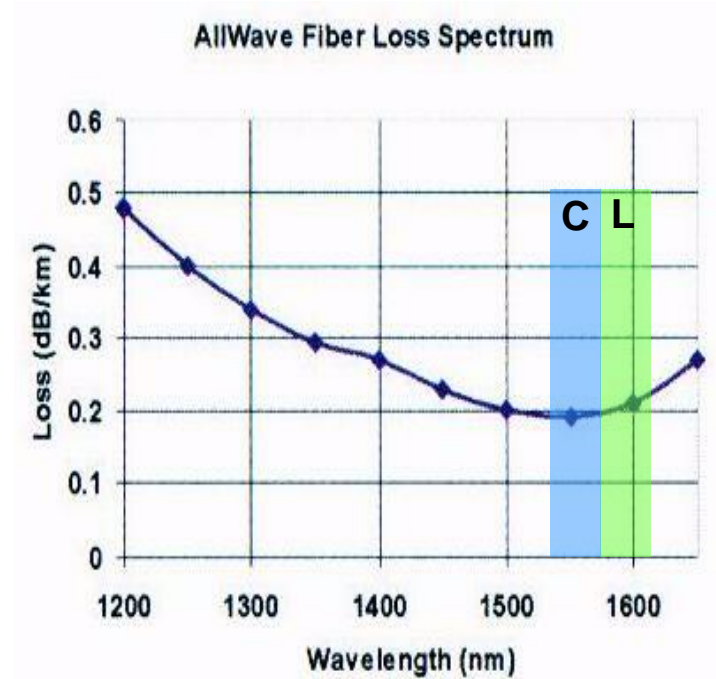
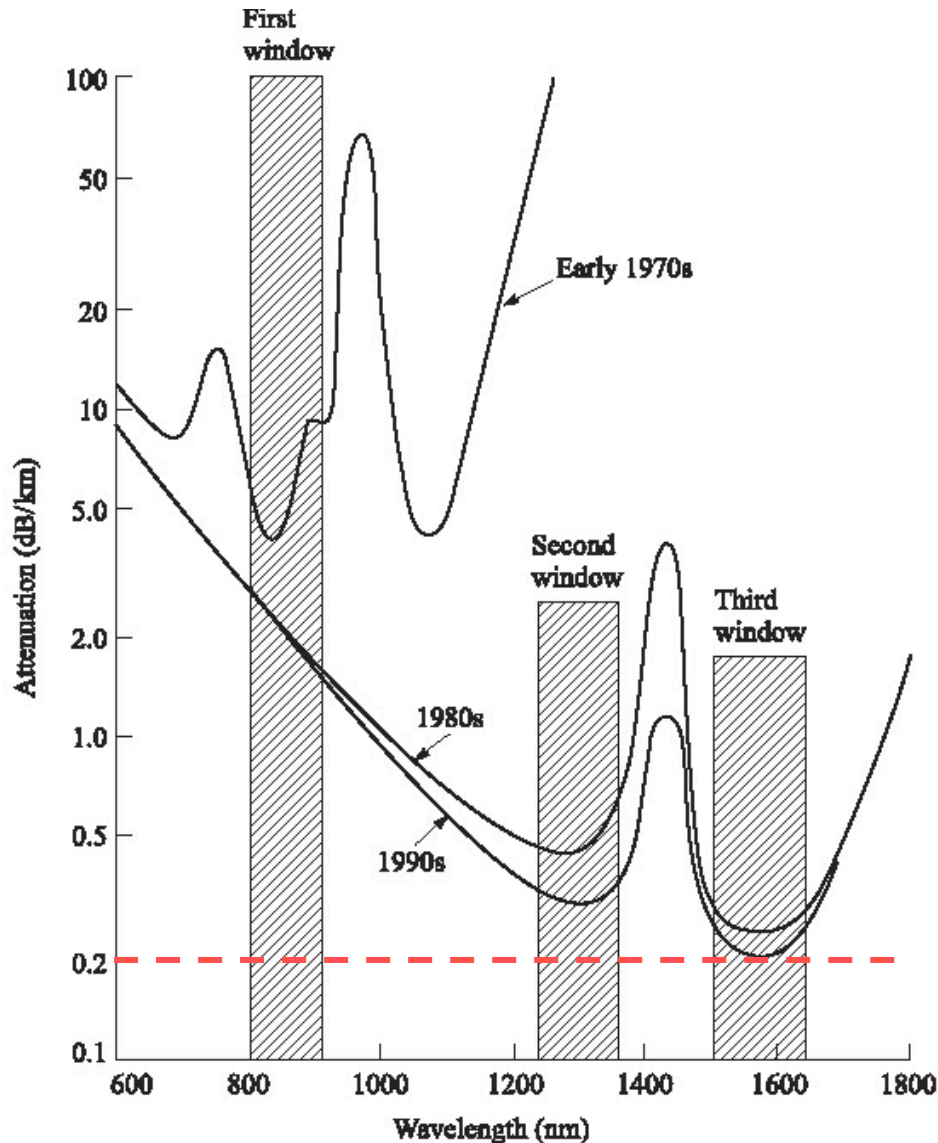
Power attenuation constant  $\alpha$  (unit  $\text{km}^{-1}$ ) expressed by attenuation  $a$  (unit dB).

$$P(z) = P_0 e^{-\alpha z}, \quad a = 10 \lg \frac{P_0}{P(z)} = \alpha z 10 \lg e = 4.34 \alpha z$$

**Fig. 2.3.** Attenuation of Ge-doped ( $\Delta = 0.25\%$ ) singlemode fibre. VAD: produced with VAD-technology MCVD: produced with MCVD-technology. Unregelmäßigkeiten des Wellenleiters = irregularities of waveguide, berechnete Gesamtdämpfung = calculated total attenuation, gemessene Gesamtdämpfung = measured total attenuation, Rayleigh-Streuung = Rayleigh scattering



# Properties of Silica Glass — History



Modern communication fibre



# Properties of Silica Glass — Absorption by (OH<sup>-</sup>) Bonds

(OH<sup>-</sup>)-bond absorption is most important. Fundamental resonance  $\lambda_{\text{OH}} = 2.72 \mu\text{m}$  (110 THz). Harmonics and combinations:  $\lambda_{\text{OH}} = 2.22, 1.90, 1.38, 1.24, 1.13, 0.945, 0.88 \mu\text{m}$ . With MCVD technology (modified chemical vapour deposition), relative (OH<sup>-</sup>)-weights of 0.1 ppm (1 ppm  $\hat{=}$   $10^{-6}$ ) possible. VAD (vapour axial deposition) with dehydrated preform sets a lower limit of 1 ppb. Typical loss peaks at  $\lambda_{\text{OH}} = 1.38, 1.24, 0.945 \mu\text{m}$  are  $a/z = 5.4, 0.23, 0.083 \text{ dB / km}$  (MCVD) and  $a/z = 0.054, 0.0023, 0.00083 \text{ dB / km}$  (VAD).

At  $\lambda = 0.85, 1.3, 1.55 \mu\text{m}$  an attenuation of  $a/z = 2.2, 0.35, 0.2 \text{ dB / km}$  is feasible. Top results (undoped SiO<sub>2</sub>-core with minimum Rayleigh scattering, matched F-SiO<sub>2</sub>-cladding,  $\Delta = 0.3\%$ ) for  $\lambda = 1.3, 1.55 \mu\text{m}$  are  $a/z = 0.291, 0.154 \text{ dB / km}$ . The **basic attenuation limit** of quartz glass can be reached routinely at

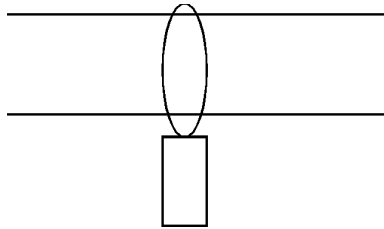
$$\lambda_{\alpha} = 1.55 \mu\text{m} \quad \text{with} \quad a/z|_{\lambda_{\alpha}} = 0.154 \text{ dB / km}.$$





# Fibre Fabrication — Overview

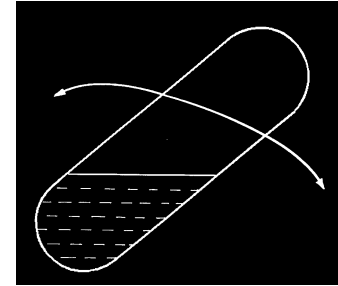
MCVD+Variations < Solution Method  
Metalorg. Compounds



1800°C

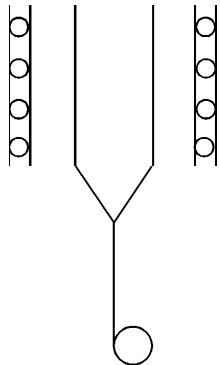
2200°C

Glass Melting



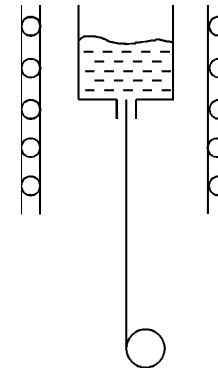
200...1000°C

Preform Drawing



2000°C

Crucible Drawing



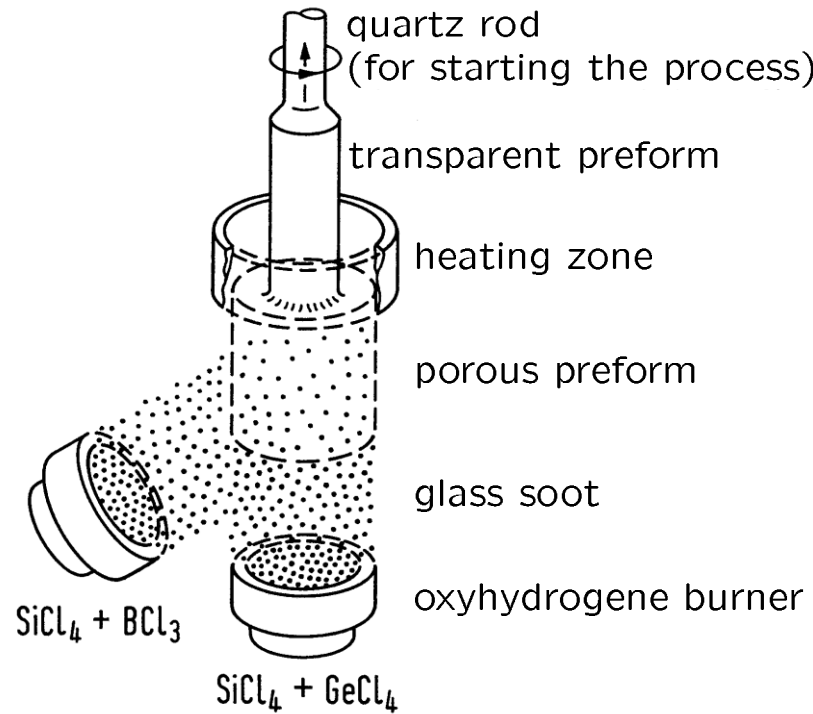
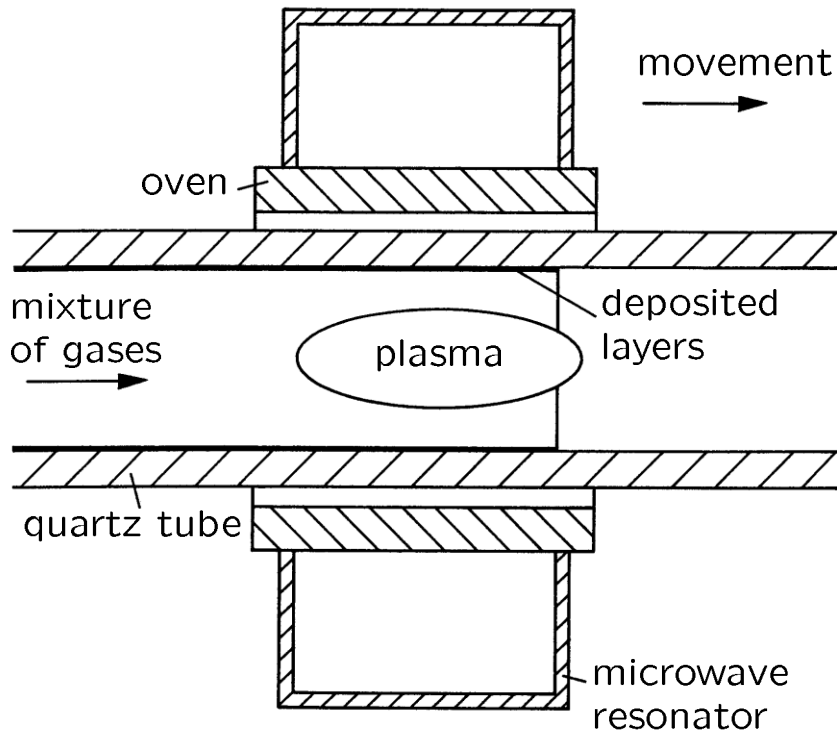
200...1000°C

Quartz Glass  
"high-silica glasses"

Chalcogenide Glass



# Fibre Fabrication — PCVD/MCVD and VAD Method



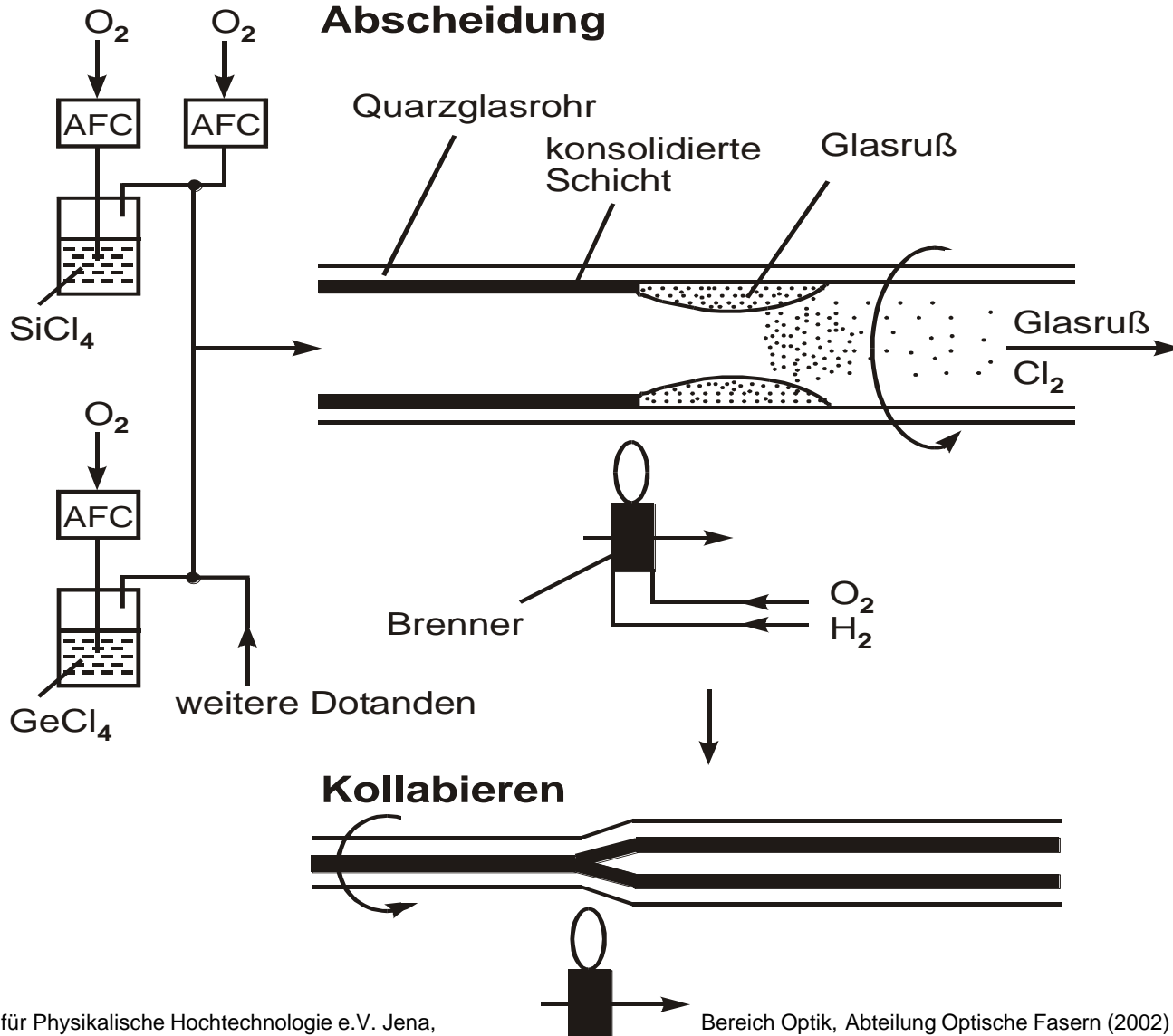
Plasma activated chemical vapour deposition (PCVD, Niederdruck-Plasma)

Similar: Modified chemical vapour deposition (MCVD)

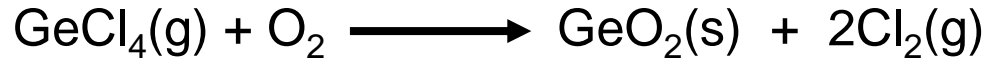
Vapour axial deposition (VAD, deposition of glass soot by flame hydrolysis)



# Fibre Fabrication — MCVD Method

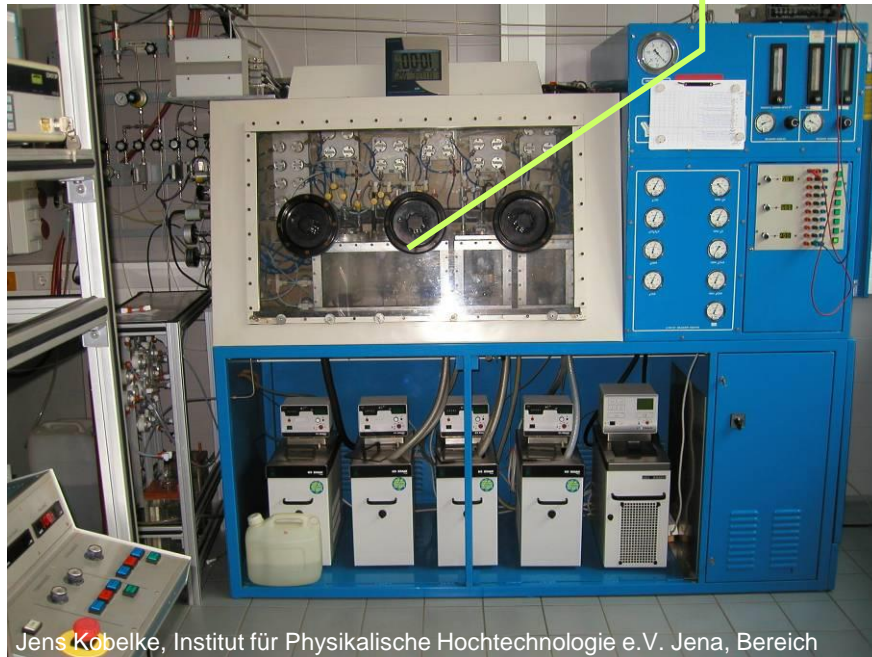


# Fibre Fabrication — MCVD Apparatus

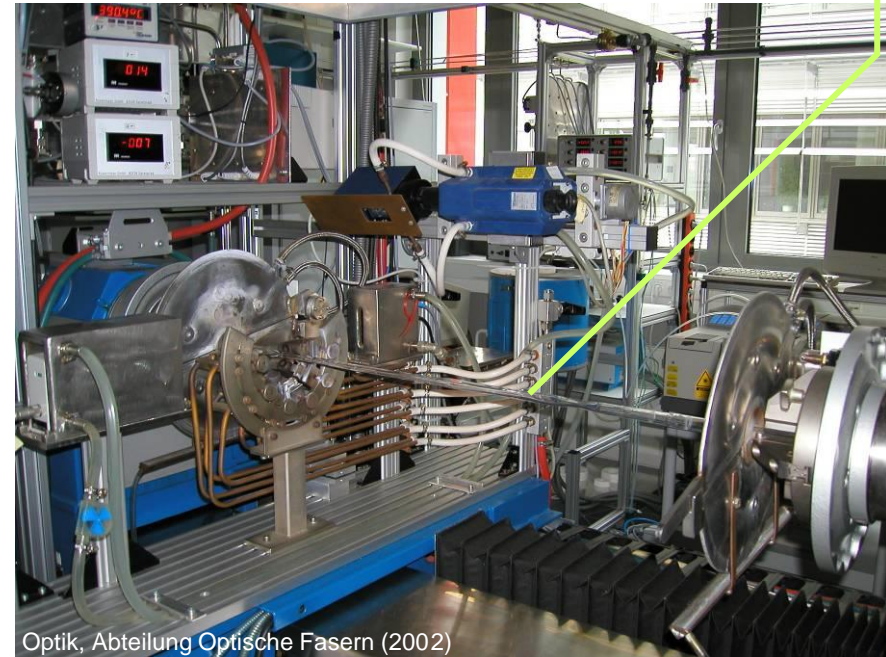


Evaporation of  $\text{SiCl}_4$ ,  
 $\text{GeCl}_4$ ,  $\text{POCl}_3$ ,  $\text{CCl}_4$ ,  
 $\text{C}_2\text{Cl}_3\text{F}_3$

Quartz glass tube



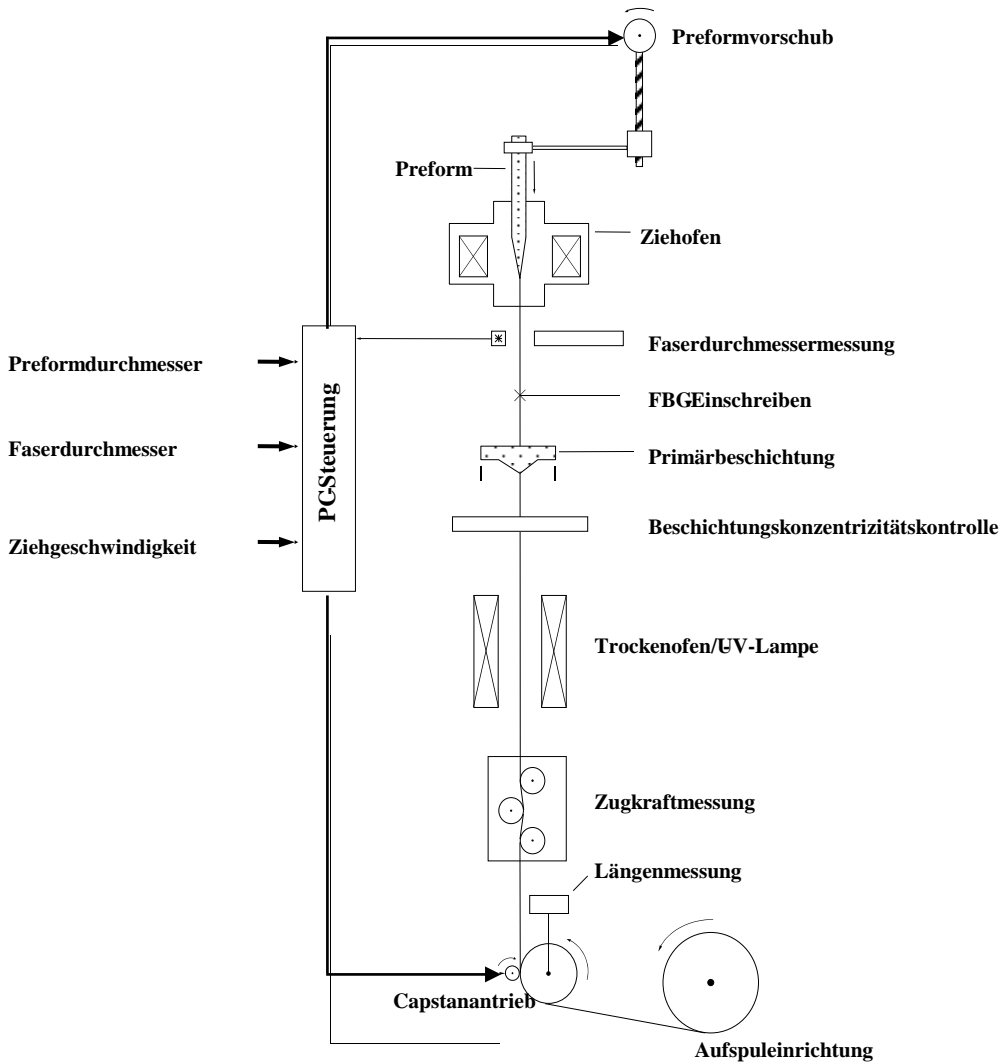
Jens Kobelke, Institut für Physikalische Hochtechnologie e.V. Jena, Bereich



Optik, Abteilung Optische Fasern (2002)

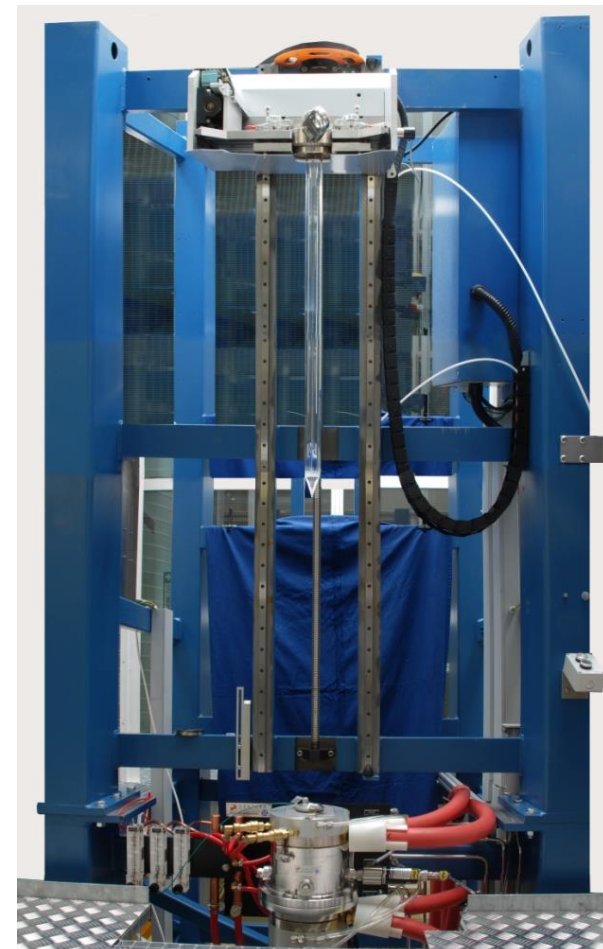
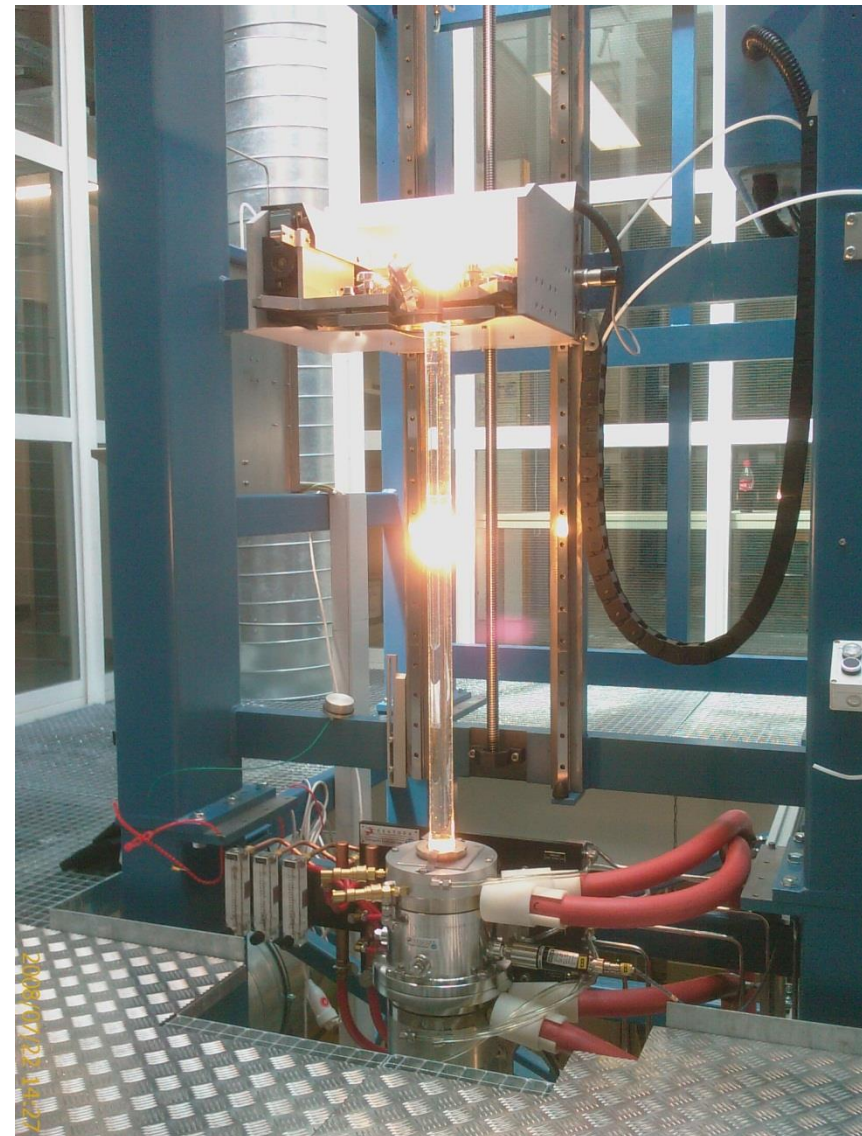


# Fibre Fabrication — Drawing Apparatus (1)






# Fibre Fabrication — Drawing Apparatus (2)



Armin Austerschulte, Institut für Strahlwerkzeuge;  
Universität Stuttgart (2008)



## Dispersion — Definition

**Real media** have losses (or possibly gain), leads to  $n(f)$ ,  $v(f)$ , and  $v(f) \neq v_g(f) \rightarrow$  “dispersion”. Different frequency components of a signal have different group delays  $t_g$  or group velocities  $v_g$ , signal becomes distorted after some length  $L$ . 

**Waveguiding properties**  $\rightarrow$  More influences on group delay which spread the signal delay times. In optical communications, the notion “dispersion” embraces all effects, which lead to a group delay time (or group velocity) spread.

If **changes of the group delay** with varying  $f$  are regarded, it is called “chromatic dispersion”, sometimes also group velocity dispersion (GVD).



# Dispersion — Material

**Group delay difference** of two plane waves (non-guided!) at optical carriers differing in  $\lambda$  by  $\Delta\lambda = \lambda - \lambda_1$ :

$$t_g(\lambda) = t_g(\lambda_1) + \frac{dt_g}{d\lambda}(\lambda - \lambda_1) + \frac{1}{2!} \frac{d^2 t_g}{d\lambda^2} (\lambda - \lambda_1)^2 + \dots,$$
$$\Delta t_g = t_g(\lambda) - t_g(\lambda_1) = \frac{dt_g}{d\lambda} \Delta\lambda + \frac{1}{2!} \frac{d^2 t_g}{d\lambda^2} (\Delta\lambda)^2 + \dots$$

**“Material dispersion”**. Length related group delay difference:

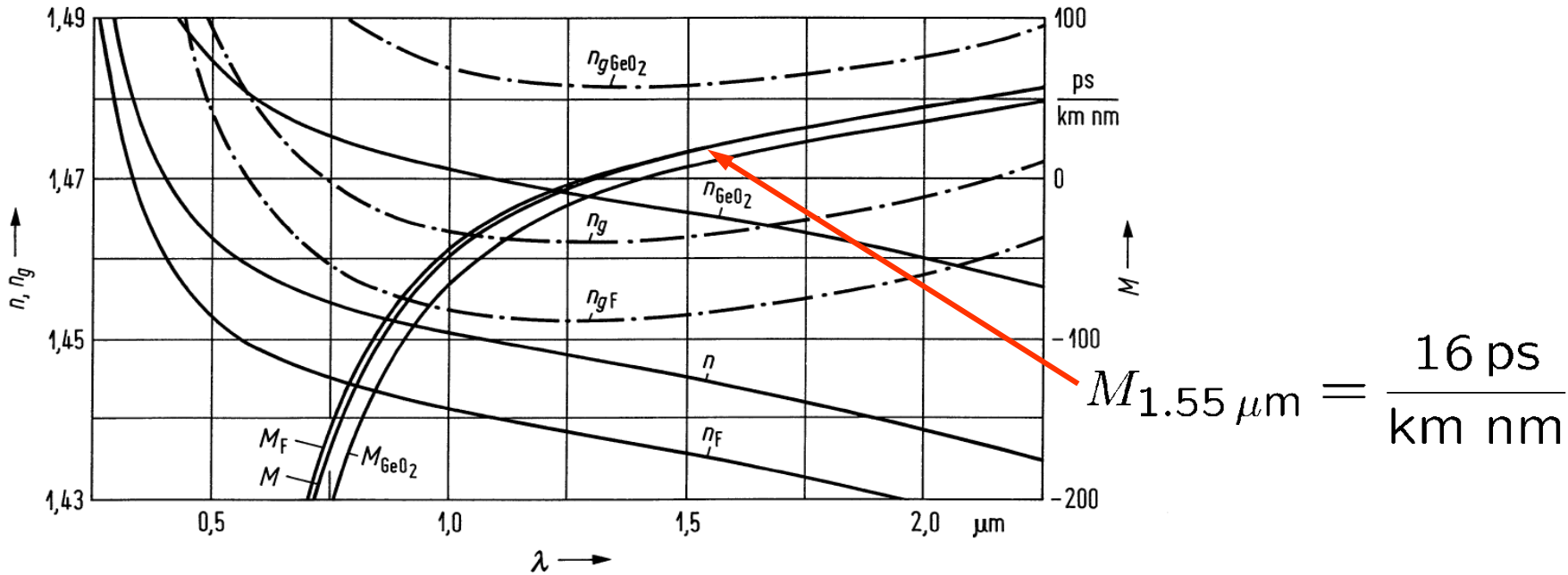
$$\frac{\Delta t_g}{L} = M \Delta\lambda + N (\Delta\lambda)^2 + \dots, \quad \frac{t_g}{L} = \frac{dk}{d\omega} = \frac{n_g}{c}, \quad M = \frac{1}{c} \frac{dn_g}{d\lambda}, \quad N = \frac{1}{2c} \frac{d^2 n_g}{d\lambda^2}$$

**First-order material dispersion  $M$**  dominates if  $M(\lambda_0) \neq 0$ . Condition  $M(\lambda_0) = 0$  is (inaccurately) called “zero material dispersion wavelength”. Material dispersion does not disappear, second-order material dispersion  $N$  takes over. Fused silica:

$$N_0 \approx 5.3 \times 10^{-2} \text{ ps / (km nm}^2\text{)}, \quad 2N_0\lambda_0 \approx 135 \text{ ps / (km nm)}$$



# Dispersion — Data



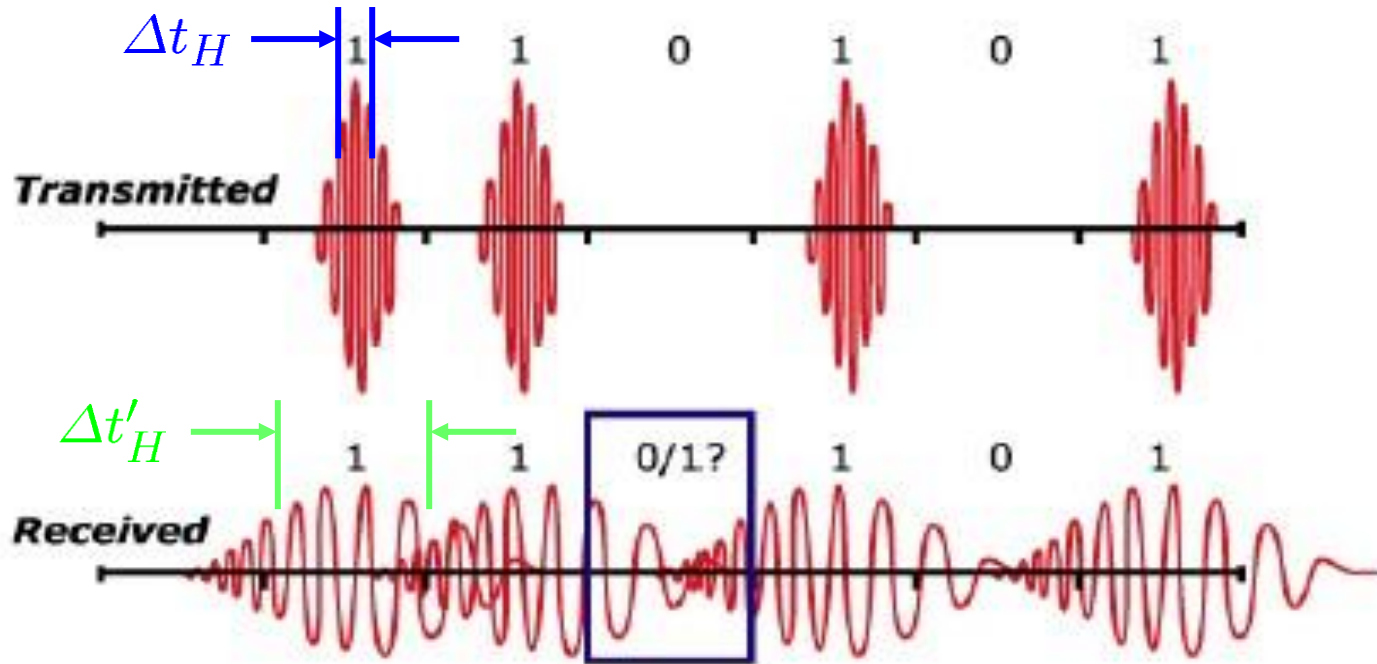
**Fig. 2.4.** Refractive index  $n$ , group index  $n_g$  and material dispersion coefficient  $M$ , computed using the so-called Sellmeier coefficients for pure  $\text{SiO}_2$  and (appropriately subscripted) for  $\text{SiO}_2$  with dopings of 2 mol % F, 13.3 mol %  $\text{GeO}_2$ . Zeros of  $M$  are at  $\lambda_{0\text{F}} = 1.2649 \mu\text{m}$ ,  $\lambda_0 = 1.2758 \mu\text{m}$ ,  $\lambda_{0\text{GeO}_2} = 1.3722 \mu\text{m}$

$$\frac{\Delta t_g}{L} = M \Delta\lambda + N (\Delta\lambda)^2 + \dots, \quad \frac{t_g}{L} = \frac{dk}{d\omega} = \frac{n_g}{c}, \quad M = \frac{1}{c} \frac{dn_g}{d\lambda}, \quad N = \frac{1}{2c} \frac{d^2 n_g}{d\lambda^2}$$





# Dispersion — Physical Meaning



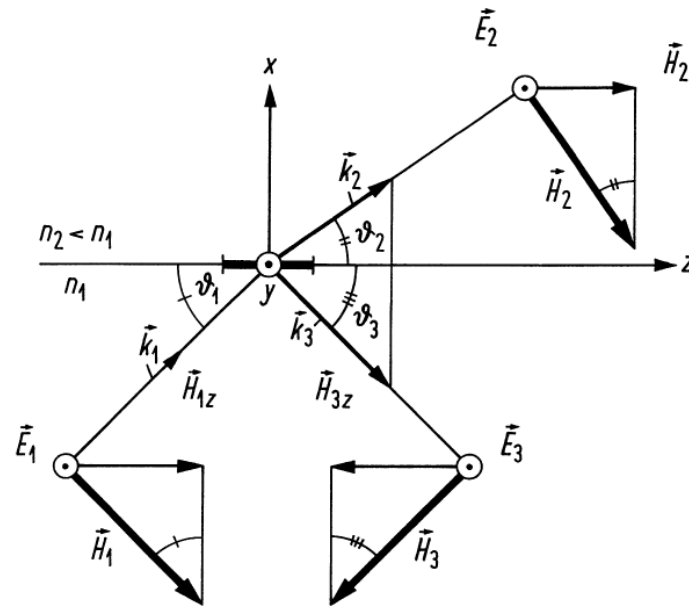
$M(1.55 \mu\text{m}) = 16 \text{ ps}/(\text{km nm})$ : Homogeneous medium. Gaussian impulse, half-power width  $\Delta t_H$ , propagates  $L = 1 \text{ km}$ . Gaussian spectrum of modulated source, width  $\Delta\lambda = 1 \text{ nm}$   
 $\Rightarrow$  Impulse broadened by  $\Delta t_g = ML\Delta\lambda = 16 \text{ ps}$ . Total width:

$$\Delta t'_H \approx \sqrt{(\Delta t_g)^2 + (\Delta t_H)^2}$$





# Inhomogeneous Medium — Plane Waves

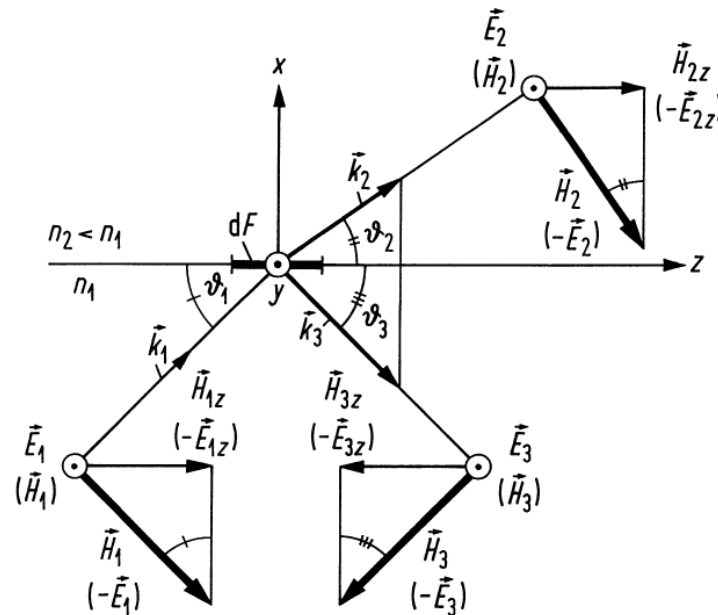


**Fig. 2.5.** Reflection and refraction of  $E$ -polarized ( $H$ -polarized) waves at a plane boundary; the subscripts 1, 2 and 3 designate the incident, transmitted and reflected waves, respectively.  $\odot$ -vectors point to the observer (perpendicularly out of the drawing area). (a) Reflection and refraction at the transition to the denser medium **Regions**  $n_1, n_2$ , boundary plane  $x = 0$ . Wanted: Solutions for incident plane wave ( $n_1 > n_2$ ). Ansatz: Three superimposed monochromatic plane waves:

$$\vec{\Psi}(t, \vec{r}) = \vec{\Psi} \exp(j\omega t - j\vec{k}_s \cdot \vec{r}), \quad \vec{\Psi}_s = \vec{E}_s, \vec{H}_s, \quad s = 1, 2, 3$$



# Inhomogeneous Medium — Plane Waves



**Fig. 2.5.** Reflection and refraction of  $E$ -polarized ( $H$ -polarized) waves at a plane boundary; the subscripts 1, 2 and 3 designate the incident, transmitted and reflected waves, respectively.  $\odot$ -vectors point to the observer (perpendicularly out of the drawing area). (a) Reflection and refraction at the transition to the denser medium **Regions**  $n_1, n_2$ , boundary plane  $x = 0$ . Wanted: Solutions for incident plane wave ( $n_1 > n_2$ ). Ansatz: Three superimposed monochromatic plane waves:

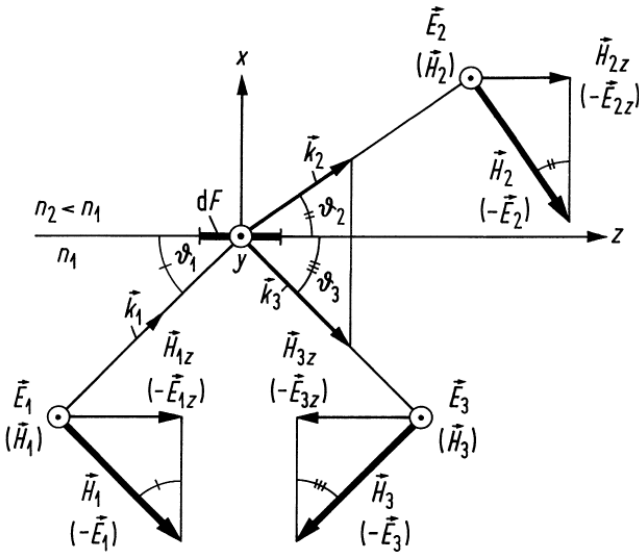
$$\vec{\Psi}(t, \vec{r}) = \vec{\Psi} \exp(j\omega t - j\vec{k}_s \cdot \vec{r}), \quad \vec{\Psi}_s = \vec{E}_s, \vec{H}_s, \quad s = 1, 2, 3$$



# Inhomogeneous Medium — Boundary Conditions

$$\vec{\Psi}(t, \vec{r}) = \vec{\Psi} \exp(j\omega t - j\vec{k}_s \cdot \vec{r}),$$

$$\vec{\Psi}_s = \vec{E}_s, \vec{H}_s, \quad s = 1, 2, 3.$$



Subscripts 1, 2, 3: Incident, transmitted and reflected waves. Only the total of three solve the problem. Vector component subscripts are coordinates  $q = x, y, z$ . For the incident wave we assume  $k_{1y} = 0$ .

$E$ -pol. ( $\vec{E}_s = E_s \vec{e}_y \parallel$  boundary plane,  $E_{sz} = 0$ , TE- or H-wave), or  
 $H$ -pol. ( $\vec{H}_s = H_s \vec{e}_y \parallel$  boundary plane,  $H_{sz} = 0$ , TM- or E-wave).

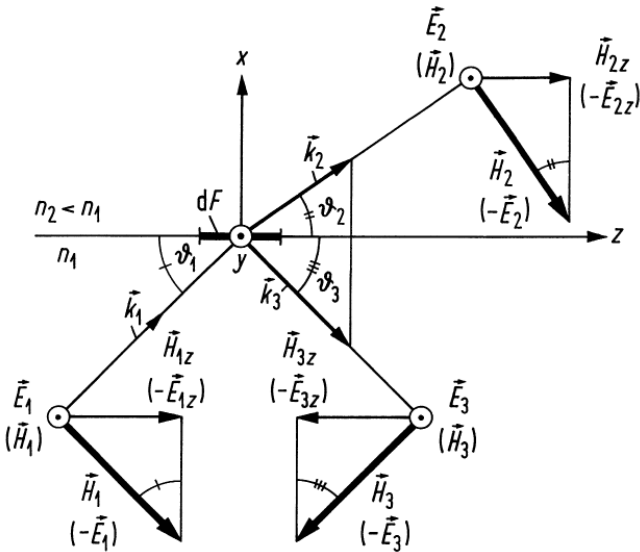
Example for transverse  $E$ - and  $H$ -components in boundary  $x = 0$ :

$$E_{2y} \exp[-j(\overbrace{k_{2x}x}^{x=0} + \overbrace{k_{2y}y}^{\rightarrow 0} + k_{2z}z)] = E_{1y} \exp[-j(\underbrace{k_{1x}x}_{x=0} + \underbrace{k_{1y}y}_{=0} + k_{1z}z)]$$

$$+ E_{3y} \exp[-j(\underbrace{k_{3x}x}_{x=0} + \underbrace{k_{3y}y}_{\rightarrow 0} + k_{3z}z)]$$



# Inhomogeneous Medium — Snell's Formula



$$k_{1y} = k_{2y} = k_{3y} = 0,$$

$$k_{1z} = k_{2z} = k_{3z};$$

*E*-polarization:

$$E_{2y} = E_{1y} + E_{3y},$$

$$H_{2z} = H_{1z} + H_{3z},$$

$$|H_{sz}| = H_s \sin \vartheta_s, \quad (H_{3z} < 0),$$

$$Z_s = E_{sy} / H_{sz} = \frac{Z_0}{n_s} k_s / k_{sx},$$

$$Y_s = -H_{sy} / E_{sz} = \frac{n_s}{Z_0} k_s / k_{sx}.$$

The  $z$ -components of  $\vec{k}_s$  and the amplitudes at both sides of  $x = 0$  must be identical, so that the fields propagate in synchronism along the  $z$ -axis. **Snell's law** and the limiting **angle**  $\vartheta_{1T}$  of **total internal reflection** (TIR) follow:

$$\vartheta_1 = \vartheta_3, \quad n_1 \cos \vartheta_1 = n_2 \cos \vartheta_2, \quad \cos \vartheta_{1T} = \frac{n_2}{n_1}$$

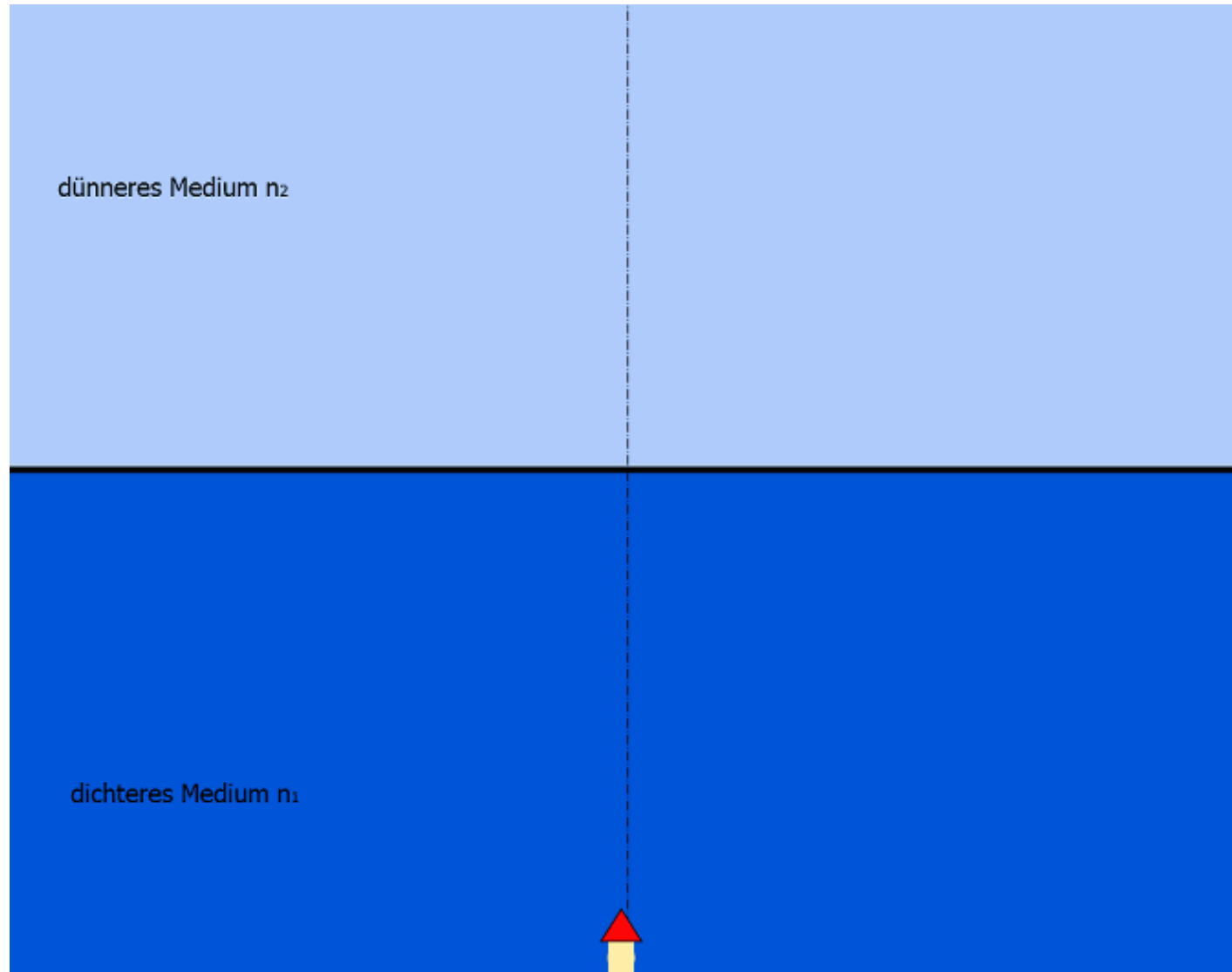


# LECTURE 5

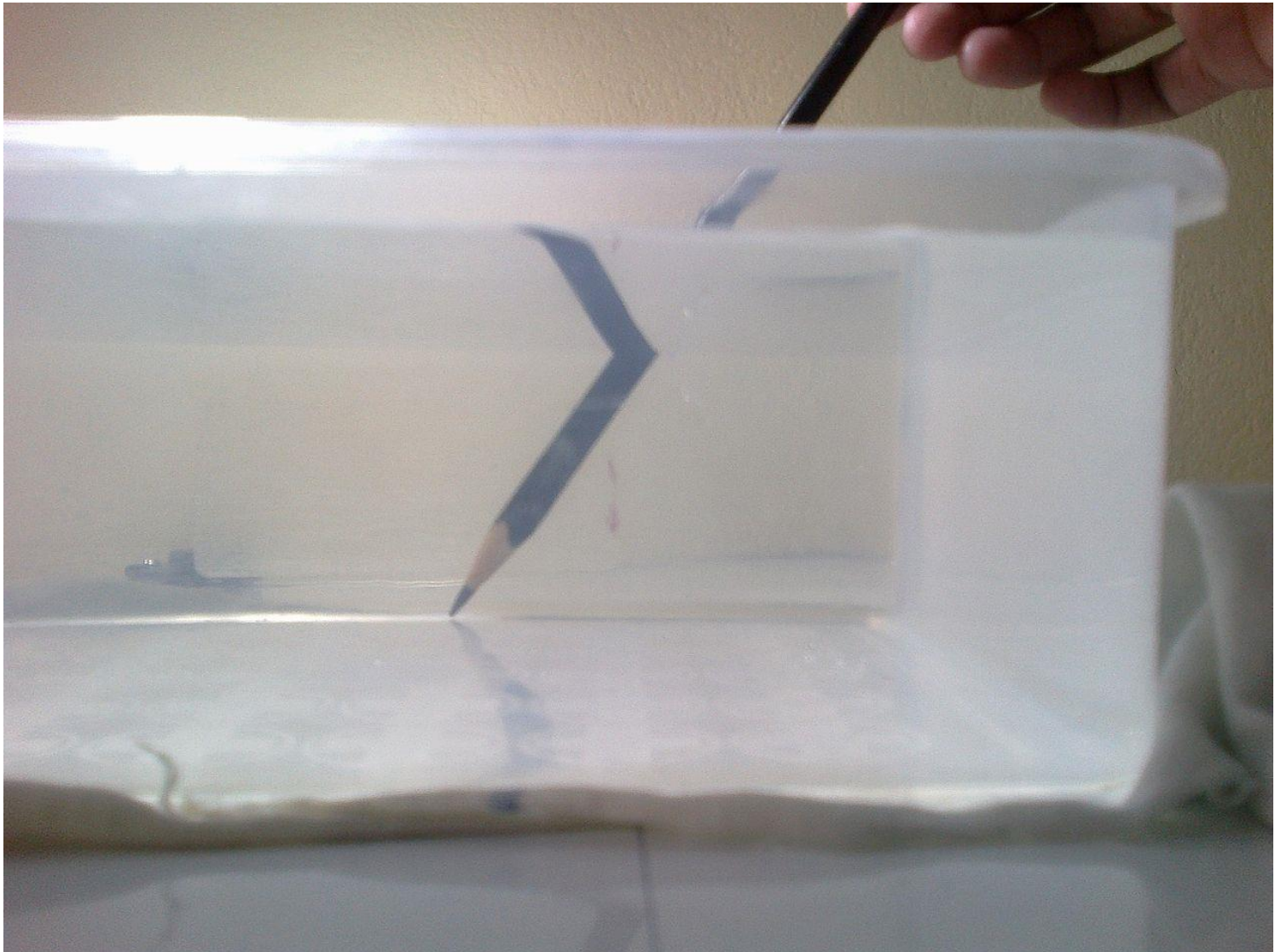




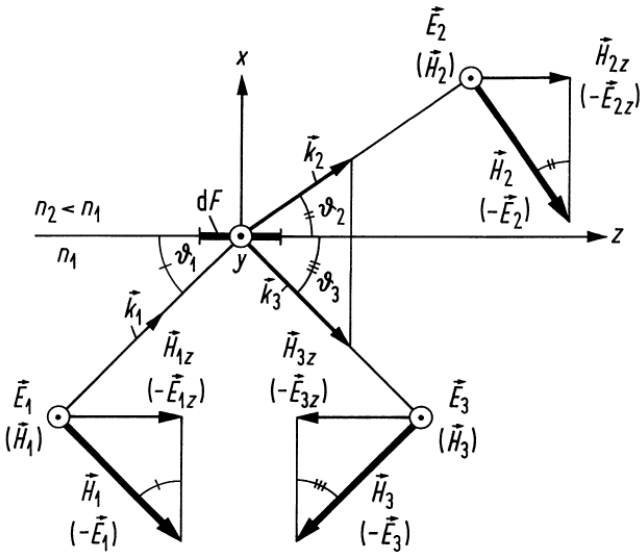
# Demonstration of Total Internal Reflection (1)



## Demonstration of Total Internal Reflection (2)



# Inhomogeneous Medium — Fresnel's Formula Derived



$$k_{1y} = k_{2y} = k_{3y} = 0,$$

$$k_{1z} = k_{2z} = k_{3z};$$

*E*-polarization:

$$E_{2y} = E_{1y} + E_{3y},$$

$$H_{2z} = H_{1z} + H_{3z},$$

$$|H_{sz}| = H_s \sin \vartheta_s, \quad (H_{3z} < 0),$$

$$Z_s = E_{sy} / H_{sz} = \frac{Z_0}{n_s} k_s / k_{sx},$$

$$Y_s = -H_{sy} / E_{sz} = \frac{n_s}{Z_0} k_s / k_{sx}.$$

Amplitude reflection coefficient  $r_E$  in *E*-polarization:

$$r_E = \frac{E_3}{E_1} = \frac{E_{3y}}{E_{1y}} = \frac{E_{2y}}{E_{1y}} - 1$$

$$\frac{E_{2y}}{E_{1y}} = \frac{Z_2}{Z_1} \frac{H_{2z}}{H_{1z}}$$

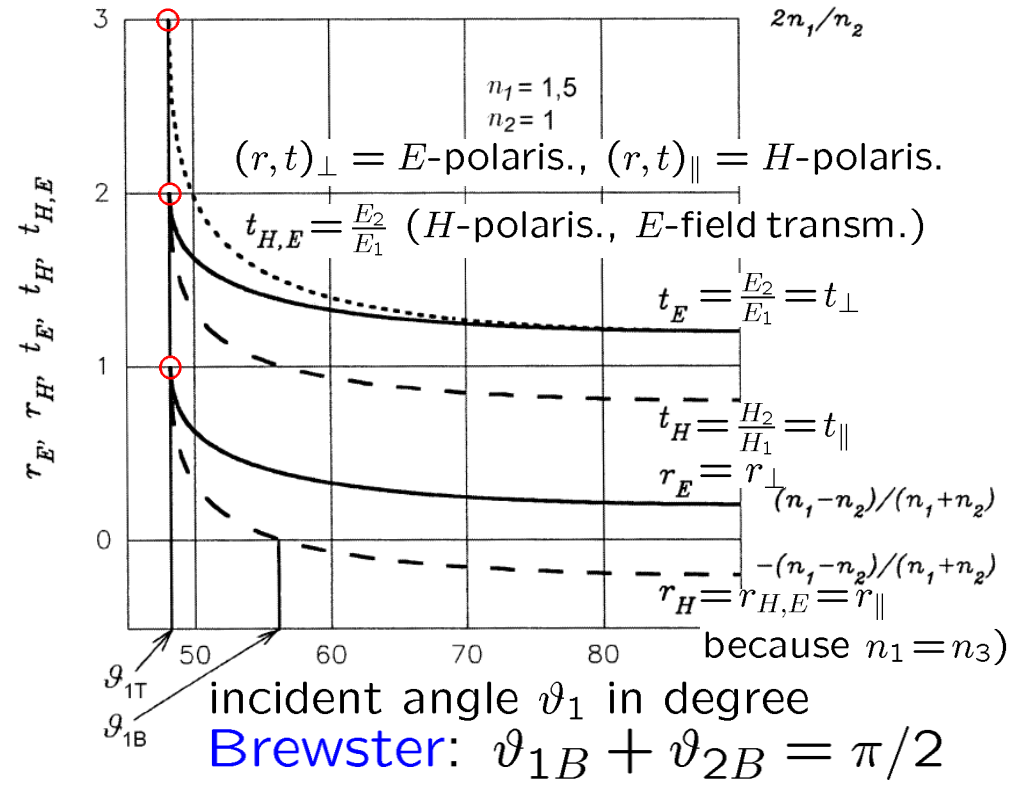
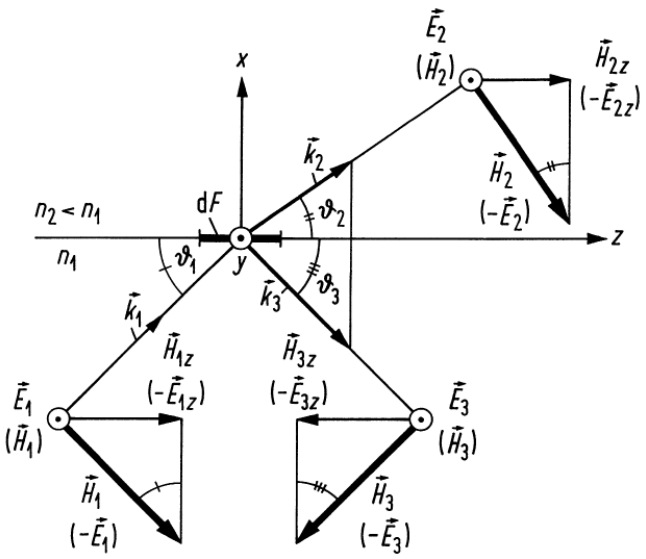
$$\frac{H_{2z}}{H_{1z}} = 1 + \frac{H_{3z}}{H_{1z}}$$

$$\frac{H_{3z}}{H_{1z}} = \frac{-E_{3y}}{Z_1 H_{1z}} = \frac{-E_{3y}}{E_{1y}}$$

$$r_E = \frac{E_3}{E_1} = \frac{E_{3y}}{E_{1y}} = \frac{Z_2}{Z_1} \left( 1 - \frac{E_{3y}}{E_{1y}} \right) - 1 \Rightarrow \frac{E_{3y}}{E_{1y}} \left( \frac{Z_2}{Z_1} + 1 \right) = \frac{Z_2}{Z_1} - 1 \Rightarrow r_E = \frac{Z_2 - Z_1}{Z_2 + Z_1}$$



# Inhomogeneous Medium — Below and at the TIR Angle



Always  $\vartheta_1 > \vartheta_2$  if  $n_2 < n_1$ .

At  $\vartheta_1 = \vartheta_{1T} \rightarrow \vartheta_2 = 0$ .

**Fresnel's formulae:**

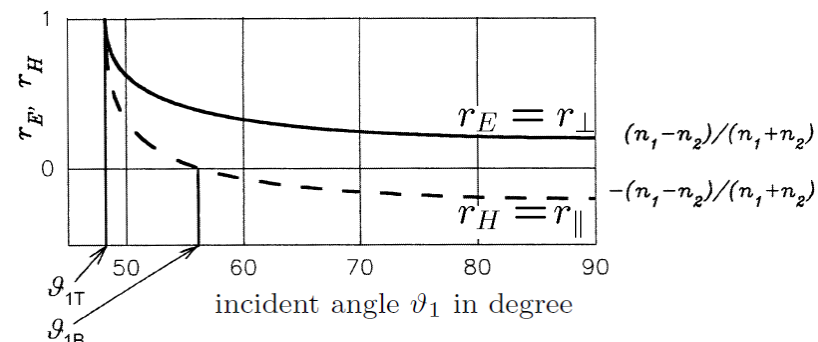
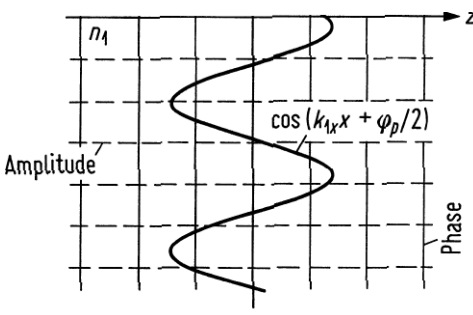
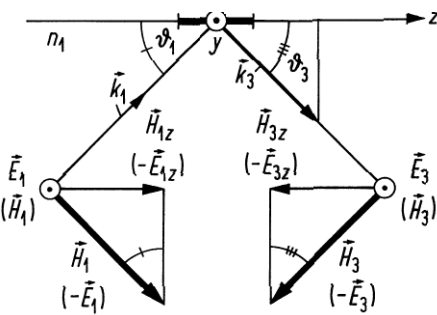
**Fig. 2.6.** Amplitude reflection and transmission coefficients as a function of incident angle  $\vartheta_1$  for  $n_1 = 1.5$ ,  $n_2 = 1$ . (glass-air interface). Einfallswinkel  $\vartheta_1$  in Grad = incident angle  $\vartheta_1$  in degree

$$r_E = \frac{E_3}{E_1} = \frac{Z_2 - Z_1}{Z_2 + Z_1} = \frac{k_{1x} - k_{2x}}{k_{1x} + k_{2x}} = \frac{n_1 \sin \vartheta_1 - n_2 \sin \vartheta_2}{n_1 \sin \vartheta_1 + n_2 \sin \vartheta_2},$$

$$r_H = \frac{H_3}{H_1} = \frac{Y_2 - Y_1}{Y_2 + Y_1} = \frac{n_2^2 k_{1x} - n_1^2 k_{2x}}{n_2^2 k_{1x} + n_1^2 k_{2x}} = \frac{n_2 \sin \vartheta_1 - n_1 \sin \vartheta_2}{n_2 \sin \vartheta_1 + n_1 \sin \vartheta_2}$$



# The Different Signs of $r_E$ and $r_H$ — Perpendicular Incidence, $k_z=0$



Incident (upwards) and reflected (downwards) waves form standing wave. Reflection coefficients  $-r_E = r_H$ ,  $|r_E| = r_H = r_{||} = 1$ ,  $\varphi_p = \pi$  for “short circuit”  $n_1 \ll n_2$ , i. e.,  $E$  ( $\hat{=}$  voltage) is zero,  $H$  ( $\hat{=}$  current) doubles at  $x = 0$ ). TE and TM waves indiscriminate. No energy transport along  $x$ -direction,  $E$  and  $H$  out of phase by  $\pi/2$ :

TE wave: 
$$E_{1y}(t, \vec{r}) = E_{1y} e^{j\omega t} \left( \underbrace{e^{-jk_{1x}x} - e^{+jk_{1x}x}}_{=-j2 \sin(k_{1x}x)} \right)$$

Impedance  $Z$  ( $x \leq 0$ ):

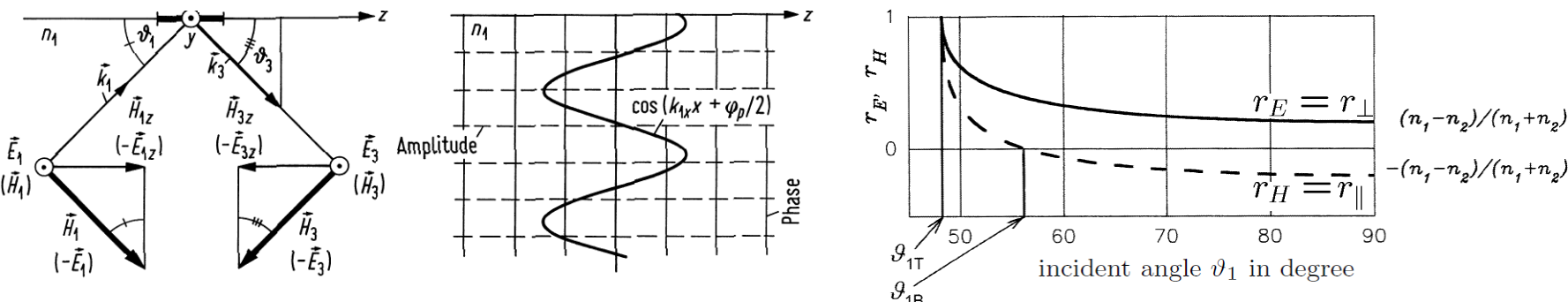
$$\frac{E_{1y}(t, \vec{r})}{H_{1z}(t, \vec{r})} = -j \frac{Z_0}{n_1} \tan(k_{1x}x) \quad H_{1z}(t, \vec{r}) = H_{1z} e^{j\omega t} \left( \underbrace{e^{-jk_{1x}x} + e^{+jk_{1x}x}}_{=2 \cos(k_{1x}x)} \right),$$

identical to TM wave: 
$$H_{1y}(t, \vec{r}) = H_{1y} e^{j\omega t} \left( \underbrace{e^{-jk_{1x}x} + e^{+jk_{1x}x}}_{=2 \cos(k_{1x}x)} \right)$$

[http://upload.wikimedia.org/wikipedia/commons/7/7d/Standing\\_wave\\_2.gif](http://upload.wikimedia.org/wikipedia/commons/7/7d/Standing_wave_2.gif)



# The Different Signs of $r_E$ and $r_H$ — Perpendicular Incidence, $k_z=0$



Incident (upwards) and reflected (downwards) waves form standing wave. Reflection coefficients  $r_E = -r_H$ ,  $r_E = |r_H| = r_\perp = 1$ ,  $\varphi_p = 0$  for “open circuit”  $n_1 \gg n_2$ , i. e.,  $E$  ( $\hat{=}$  voltage) doubles,  $H$  ( $\hat{=}$  current) is zero at  $x = 0$ ). TE and TM waves indiscriminate. No energy transport along  $x$ -direction,  $E$  and  $H$  out of phase by  $\pi/2$ :

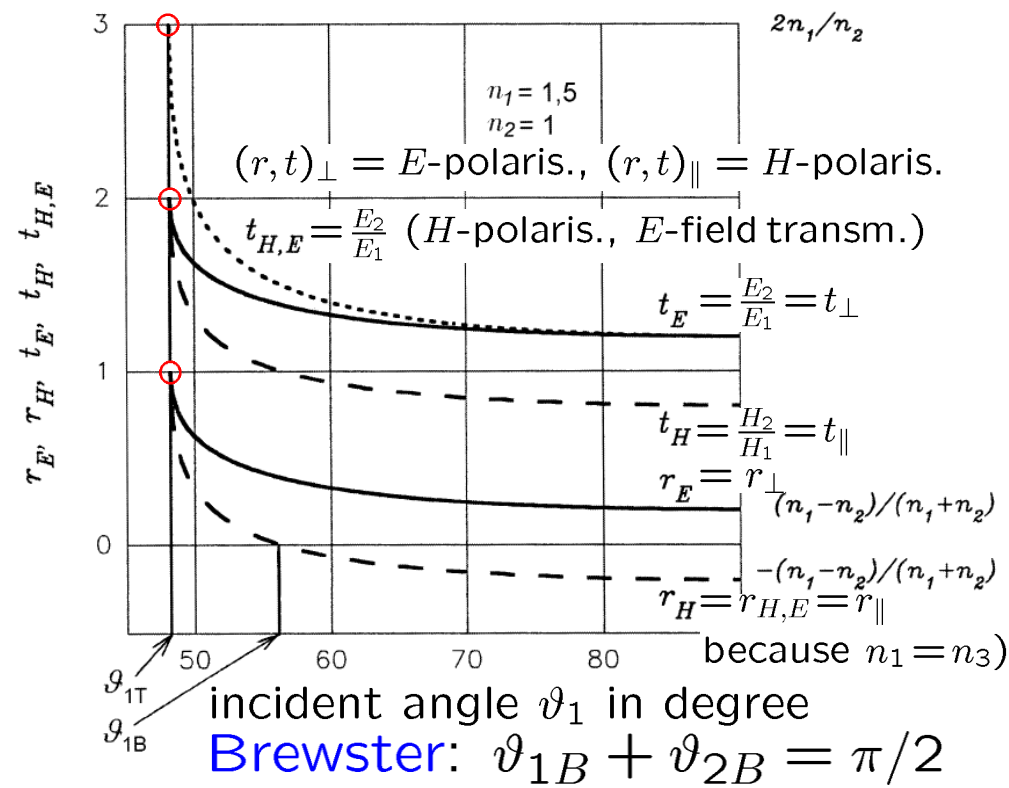
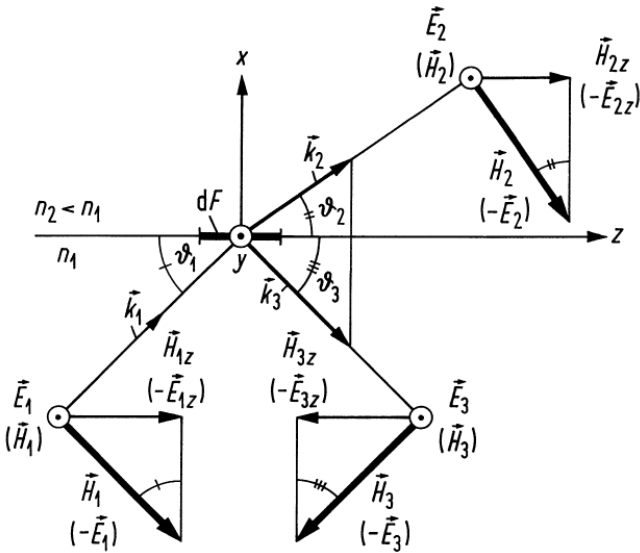
TE wave: 
$$E_{1y}(t, \vec{r}) = E_{1y} e^{j\omega t} \underbrace{\left( e^{-jk_1x} + e^{+jk_1x} \right)}_{= 2 \cos(k_1x)}$$

Impedance  $Z$  ( $x \leq 0$ ):

$$\frac{E_{1y}(t, \vec{r})}{H_{1z}(t, \vec{r})} = j \frac{Z_0}{n_1} \cot(k_1x) \quad H_{1z}(t, \vec{r}) = H_{1z} e^{j\omega t} \underbrace{\left( e^{-jk_1x} - e^{+jk_1x} \right)}_{= -j 2 \sin(k_1x)},$$

identical to TM wave: 
$$H_{1y}(t, \vec{r}) = H_{1y} e^{j\omega t} \underbrace{\left( e^{-jk_1x} - e^{+jk_1x} \right)}_{= -j 2 \sin(k_1x)}$$

# Inhomogeneous Medium — Below and at the TIR Angle



Always  $\vartheta_1 > \vartheta_2$  if  $n_2 < n_1$ .  
 At  $\vartheta_1 = \vartheta_{1T} \rightarrow \vartheta_2 = 0$ .

## Fresnel's formulae:

**Fig. 2.6.** Amplitude reflection and transmission coefficients as a function of incident angle  $\vartheta_1$  for  $n_1 = 1.5$ ,  $n_2 = 1$ . (glass-air interface). Einfallswinkel  $\vartheta_1$  in Grad = incident angle  $\vartheta_1$  in degree

$$r_E = \frac{E_3}{E_1} = \frac{Z_2 - Z_1}{Z_2 + Z_1} = \frac{k_{1x} - k_{2x}}{k_{1x} + k_{2x}} = \frac{n_1 \sin \vartheta_1 - n_2 \sin \vartheta_2}{n_1 \sin \vartheta_1 + n_2 \sin \vartheta_2},$$

$$r_H = \frac{H_3}{H_1} = \frac{Y_2 - Y_1}{Y_2 + Y_1} = \frac{n_2^2 k_{1x} - n_1^2 k_{2x}}{n_2^2 k_{1x} + n_1^2 k_{2x}} = \frac{n_2 \sin \vartheta_1 - n_1 \sin \vartheta_2}{n_2 \sin \vartheta_1 + n_1 \sin \vartheta_2}$$

# Inhomogeneous Medium — Below and at the TIR Angle

For TIR  $\vartheta_1 \leq \vartheta_{1T}$ ,  $k_{2z} > k_2 \rightarrow k_{2x}$  negative imaginary  $\rightarrow$  spatial contraction of  $\Psi_{2q}(t, \vec{r}) = E_{2q}, H_{2q}$ ,

$$k_{2x} = -\sqrt{k_2^2 - k_{2z}^2} = -j k_0 \sqrt{n_1^2 \cos^2 \vartheta_1 - n_2^2} = -j |k_{2x}^{(i)}|,$$

$$\Psi_{2q}(t, \vec{r}) = \Psi_{2q} e^{j\omega t} e^{-j k_{2x} x} e^{-j k_{2z} z} = \Psi_{2q} e^{-|k_{2x}^{(i)}| x} e^{j(\omega t - k_{2z} z)} \quad \uparrow$$

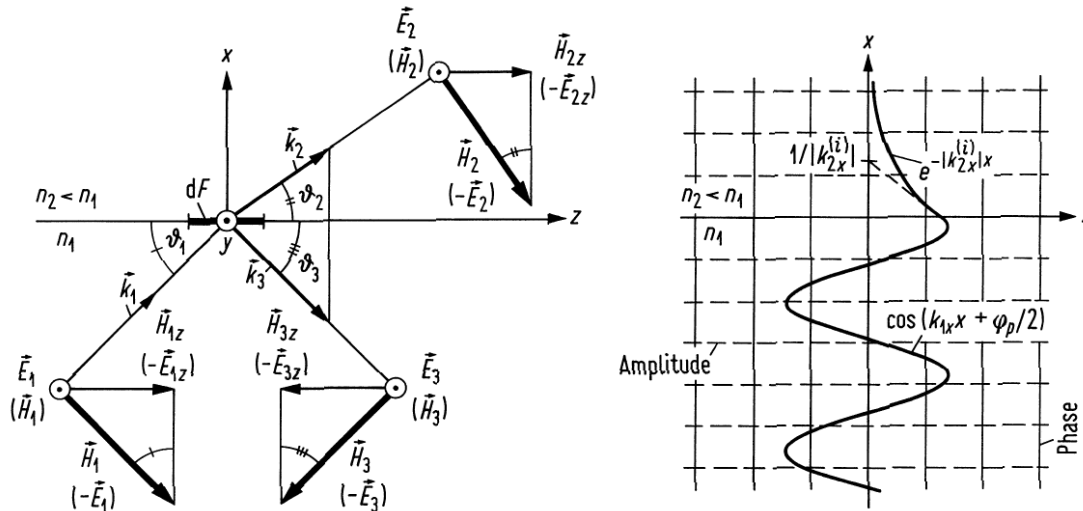
Field evanescent in  $+x$ -direction,  $\vec{k}_2 = -j |k_{2x}^{(i)}| \vec{e}_x + k_{1z} \vec{e}_z$ . For  $E$ -polarization:

$$r_E = \frac{k_{1x} - k_{2x}}{k_{1x} + k_{2x}} = \frac{A \exp \left[ j \arctan \left( |k_{2x}^{(i)}| / k_{1x} \right) \right]}{\frac{k_{1x} + j |k_{2x}^{(i)}|}{k_{1x} - j |k_{2x}^{(i)}|}} = \frac{A}{A} e^{j 2 \arctan \left( |k_{2x}^{(i)}| / k_{1x} \right)}$$

$$\varphi_E = 2 \arctan \frac{|k_{2x}^{(i)}|}{k_{1x}}, \quad \varphi_H = 2 \arctan \frac{n_1^2 |k_{2x}^{(i)}|}{n_2^2 k_{1x}}$$



# Inhomogeneous Medium — TIR Summary



Incident & reflected waves form standing wave ( $\varphi_E$  of  $r_E$  ignored):

$$\Psi_{1q}(t, \vec{r}) = \Psi_{1q} e^{j\omega t} \underbrace{\left( e^{-jk_1 x} + e^{+jk_1 x} \right)}_{=2 \cos(k_1 x)} e^{-jk_1 z}$$

In cladding decay as  $\exp(-|k_2^{(i)}|x)$ . Power reflection factors:

$$\frac{1}{2} n_2 |E_2|^2 dF \sin \vartheta_2 = \frac{1}{2} n_1 |E_1|^2 dF \sin \vartheta_1 - \frac{1}{2} n_1 |E_3|^2 dF \sin \vartheta_1,$$

$$\frac{\frac{1}{2} n_2 |E_2|^2 dF \sin \vartheta_2}{\frac{1}{2} n_1 |E_1|^2 dF \sin \vartheta_1} = T_p = 1 - R_p, \quad R_p = |r_p|^2, \quad p = E, H$$

⊥ glass-air:  $R_E = R_H = 4\%$ ; ⊥ GaAs-air:  $R_E = R_H = 32\%$



# Waveguiding — Requirements

**Waveguiding achieved** by surrounding a core along  $z$ -axis with lower density cladding, i. e., refractive index decreases away from axis, core-cladding or graded-index waveguide.

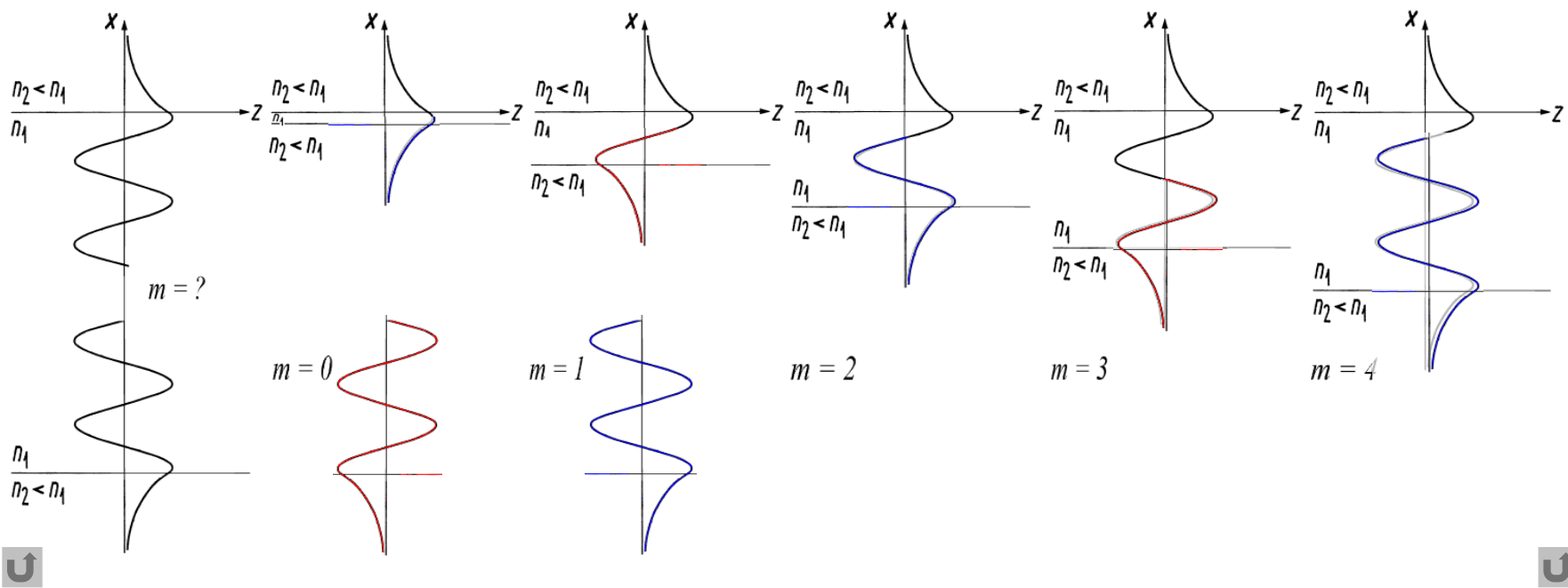
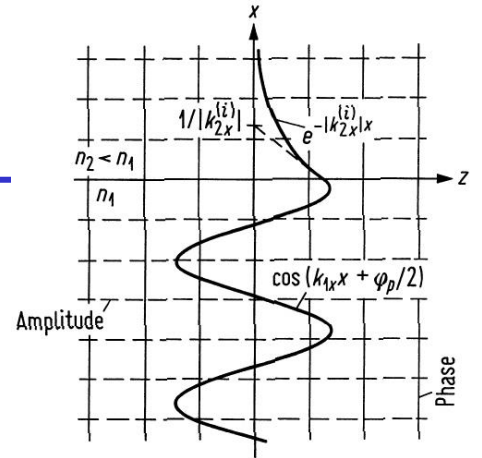
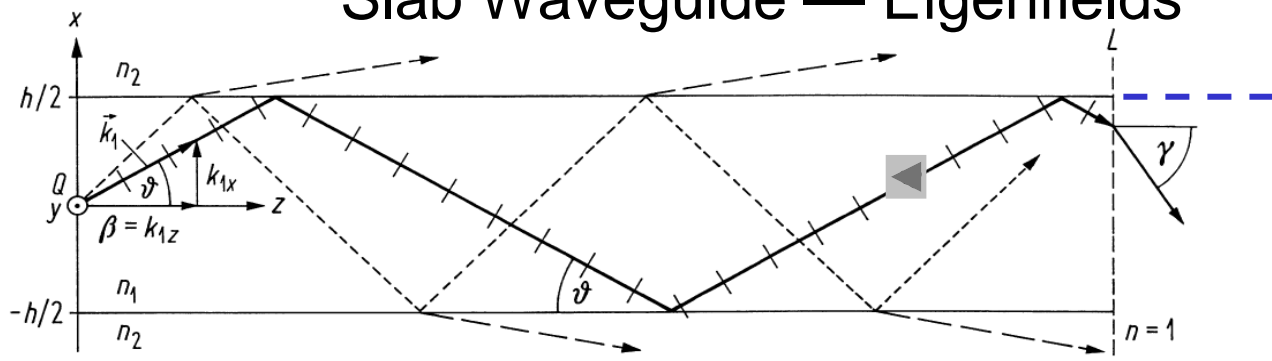
**Light waveguides made** from transparent dielectrics like glass or semiconductors based on Si, GaAs or InP. Symmetric slabs and strips particularly important: Simple models for waveguiding in, e. g., semiconductor lasers (laser diodes).

**All essential light waveguide properties studied** at little mathematical cost. Physical insight can then be transferred to more complex waveguiding structures.





# play Slab Waveguide — Eigenfields



**Fig. 2.8.** Modes in a slab waveguide according to the results of Fig. 2.5(b). The upper boundary (UB) remains spatially fixed. The lower boundary (LB) is shifted to a distance  $x_{UB} - x_{LB} = h$  such that the standing waves originating from the reflections at the UB and LB are in phase. From left to right: UB and LB at arbitrary distance, no phase match ( $m = ?$ ). LB at minimum distance (fundamental mode  $m = 0$ ). LB moved to the next possible phase match positions ( $m = 1, 2, 3, 4, \dots$ )

# Slab Waveguide — Num. Aperture and Propag. Constant

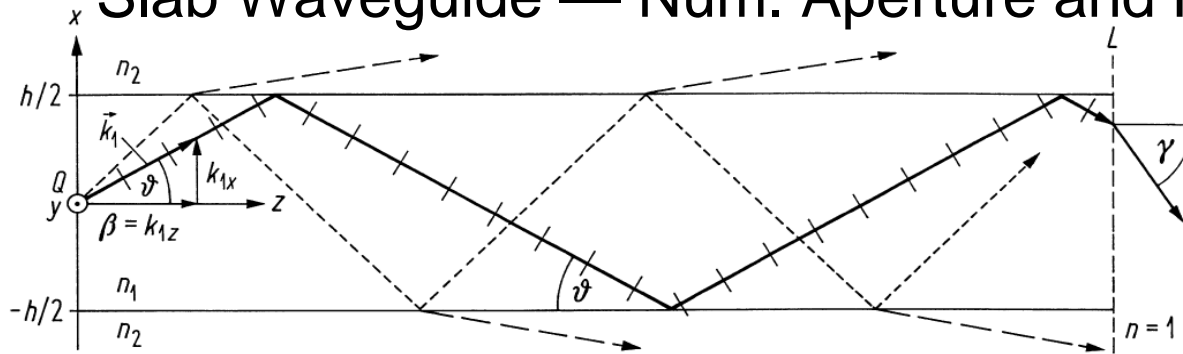


Fig. 2.7. Slab waveguide. Guided (—) and radiated waves (---)

**Angle  $\gamma_N$**  defines light-shadow boundary in far-field, may be measured outside and is preferred to  $\vartheta_T$ . With Snell's law:

$$\sin \gamma_N = n_1 \sin \vartheta_T = \sqrt{n_1^2 - n_2^2},$$

$$A_N = \sqrt{n_1^2 - n_2^2} = n_1 \sqrt{2\Delta}, \quad \Delta = \frac{n_1^2 - n_2^2}{2n_1^2} \approx \{n_1 \approx n_2\} \approx \frac{n_1 - n_2}{n_1}$$

**Propag. const.** (phase veloc.  $\frac{\omega}{\beta} > \frac{c}{n_1}$  larger than speed of light in core!)

$$\beta = k_{1z} = k_1 \cos \vartheta = k_{2z} \quad (k_2 < \beta < k_1), \quad n_e = \frac{\beta}{k_0} \quad (n_2 < n_e < n_1),$$

$$k_{1x} = k_1 \sin \vartheta = \sqrt{k_1^2 - \beta^2}, \quad k_{2x} = \pm j \sqrt{\beta^2 - k_2^2}$$



# Slab Waveguide — Notation and Eigenvalue Condition

Transverse core phase constant (core parameter “transversales Phasenmaß”)  $u$ , transverse cladding attenuation (cladding parameter “transversales Dämpfungsmaß”)  $w$ , normalized frequency (waveguide parameter)  $V$ , relative refractive index difference  $\Delta$ , normalized propagation constants  $B, \delta$ ,

$$u = k_{1x} \frac{h}{2} = \frac{h}{2} \sqrt{k_1^2 - \beta^2}, \quad w = |k_{2x}| \frac{h}{2} = \frac{h}{2} \sqrt{\beta^2 - k_2^2},$$
$$V = \frac{h}{2} k_0 A_N = \sqrt{u^2 + w^2}, \quad \Delta = \frac{n_1^2 - n_2^2}{2n_1^2} \approx \{n_1 \approx n_2\} \approx \frac{n_1 - n_2}{n_1},$$
$$B = \frac{\beta^2 - k_2^2}{k_1^2 - k_2^2} = \frac{w^2}{V^2} = 1 - \frac{u^2}{V^2} = 1 - \frac{\delta}{\Delta} \approx \{\Delta \ll 1\} \approx \frac{\beta - k_2}{k_1 - k_2}.$$

**Not all  $\beta$  allowed** for guided waves  $k_2 < \beta < k_1$ . Transversely consistent field at boundary planes  $x = \pm h/2$ : Matching standing waves from top and bottom:

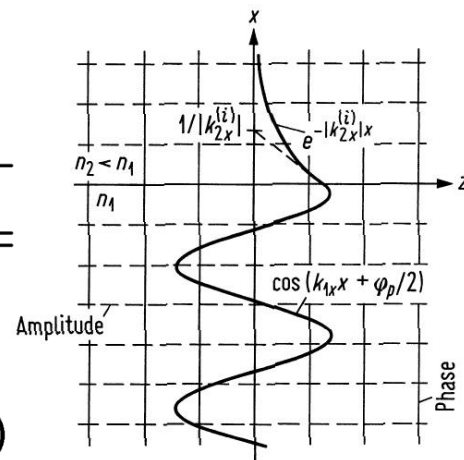
$$\cos(k_{1x}x) = \cos\left(\frac{2u}{h}x\right), \quad \sin(k_{1x}x) = \sin\left(\frac{2u}{h}x\right)$$



# Slab Waveguide — Matching the Fields

Incident (amplitude  $\Psi_{1q} e^{-j k_{1x} x} e^{-j k_{1z} z}$ ) and reflected wave (amplitude  $\Psi_{1q} r_p e^{+j k_{1x} x} e^{-j k_{1z} z} = \Psi_{1q} e^{j \varphi_p} e^{+j k_{1x} x} e^{-j k_{1z} z}$ ) superimposed:

$$e^{-j k_{1x} x} + e^{j \varphi_p} e^{+j k_{1x} x} = e^{j \varphi_p / 2} 2 \cos(k_{1x} x + \varphi_p / 2)$$



Coordinate shift from boundary to WG centre,  $x' = x + h/2$ :

$$\cos[k_{1x} x + \varphi_p / 2] = \cos[k_{1x} (x' - h/2) + \varphi_p / 2]$$

For a consistent mode which does not change its field when propagating along  $z$ ,  $x' = 0$  must be a symmetry plane:

$$\cos[k_{1x} (x' - h/2) + \varphi_p / 2] = \pm \cos[k_{1x} (-x' - h/2) + \varphi_p / 2]$$

**Symmetric** (extremum, cos) and **antisymmetric** modes (node, sin):

$$\cos(-k_{1x} h/2 + \varphi_p / 2) = \pm 1, \quad \cos(-k_{1x} h/2 + \varphi_p / 2) = 0$$



# Slab Waveguide — Eigenvalue Equation

Symmetric and antisymmetric modes:

$$\cos(-k_{1x}h/2 + \varphi_p/2) = \pm 1, \quad \cos(-k_{1x}h/2 + \varphi_p/2) = 0$$

Transverse phase difference after two total internal reflections:

$$-k_{1x}\frac{h}{2} + \frac{\varphi_p}{2} = -m\frac{\pi}{2}, \quad -2k_{1x}h + 2\varphi_p = -2m\pi, \quad -u + \frac{\varphi_p}{2} = -m\frac{\pi}{2},$$

$$\varphi_p = 2 \arctan \left( \sigma_p \frac{|k_{2x}^{(i)}|}{k_{1x}} \right),$$

$$u = \frac{\varphi_p}{2} + m\frac{\pi}{2} = \arctan \left( \sigma_p \frac{w}{u} \right) + m\frac{\pi}{2},$$

$$\tan \left( u - m\frac{\pi}{2} \right) = \sigma_p \frac{w}{u}$$

For even and odd TE- and TM-waves, we find the result:

$$\sigma_p w_{pm} = \sigma_p \sqrt{V^2 - u_{pm}^2} = \begin{cases} u_{pm} \tan u_{pm} & m = 0, 2, 4, \dots \\ -u_{pm} \cot u_{pm} & m = 1, 3, 5, \dots \end{cases}$$

$$\text{TE-wave (H-wave):} \quad p = E, \quad \sigma_E = 1$$

$$\text{TM-wave (E-wave):} \quad p = H, \quad \sigma_H = n_1^2/n_2^2$$

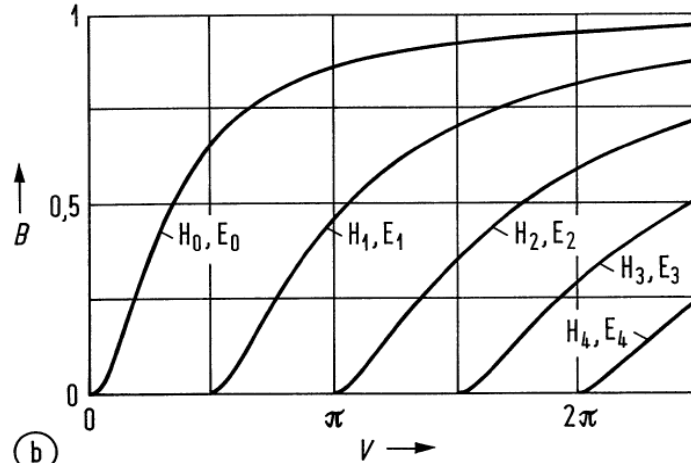
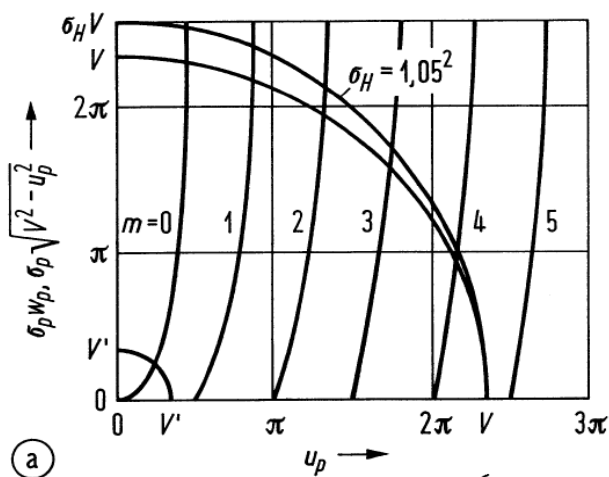




# LECTURE 6



# Slab Waveguide — Eigenvalues



$$\sigma_E = 1, \quad \sigma_H = n_1^2/n_2^2$$

$$\sigma_p w_p = \sigma_p \sqrt{V^2 - u_p^2} = \begin{cases} u_p \tan u_p & m = 0, 2, 4, \dots \\ -u_p \cot u_p & m = 1, 3, 5, \dots \end{cases} \quad \sigma_E = 1, \quad \sigma_H = \frac{n_1^2}{n_2^2}$$

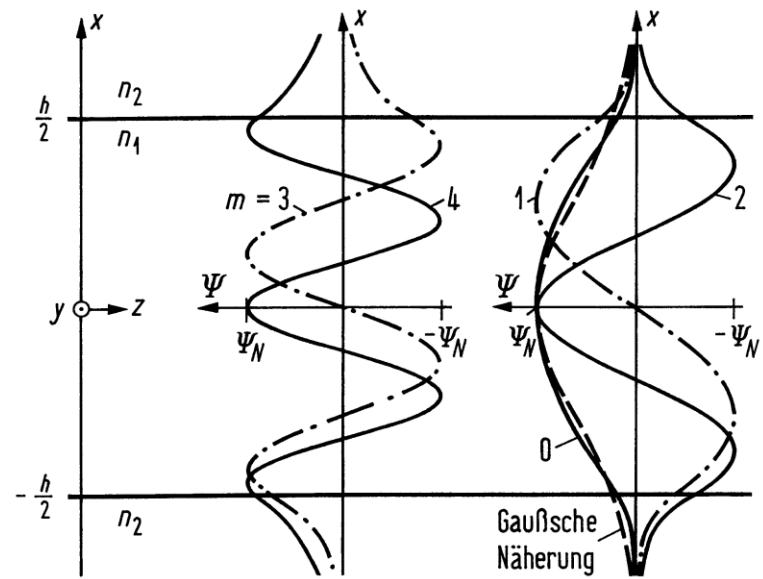
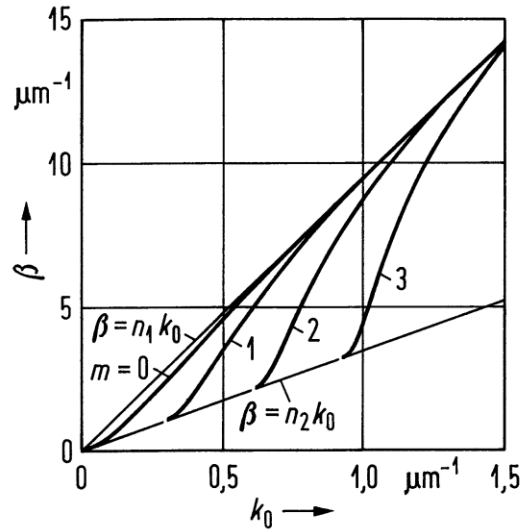
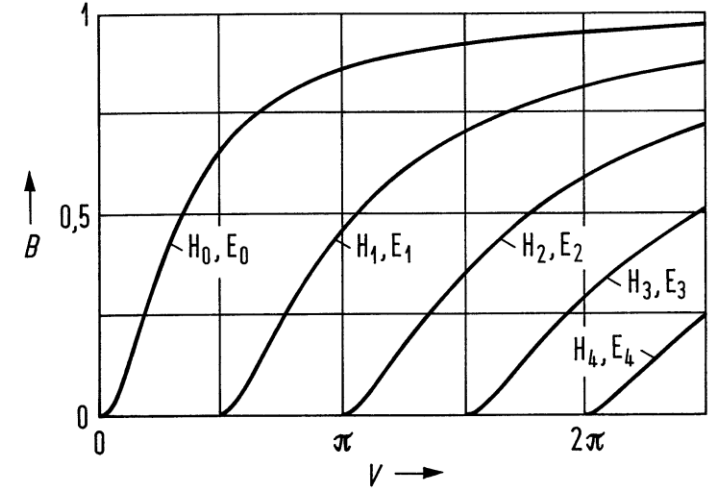
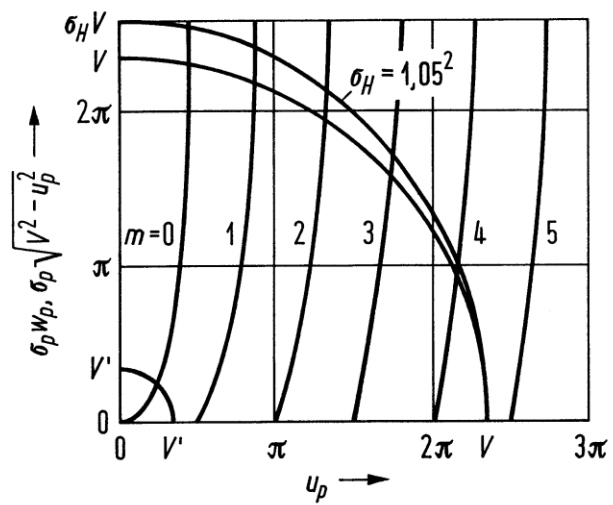
Eigenvalues of the propagation constant  $\beta$  or the core parameter  $u$ . (a) Graphical solution of the eigenvalue equation for TE-modes (H-waves,  $\sigma_E = 1$ ) and TM-modes (E-waves  $\sigma_H = 1.05^2$ ),  $V = 7.33$ .  $u_E \leq u_H$ ,  $\beta_E \geq \beta_H$ ,  $B_E \geq B_H$  (b) Normalized propagation constant for weakly guiding LWG

**Characteristic equation (eigenvalue or dispersion equation**, mathematical formulation of the graphical procedure above) defines allowed angles  $\vartheta_m$  or so-called eigenvalues  $\beta_m$ .

Waves  $\vec{\Psi}_m(\vec{r}) = \vec{\Psi}_m(x) \exp(-j\beta_m z)$  are eigenwaves or *modes* of waveguide. Fields with other propagation constants cannot propagate, are either evanescent along  $z$ , or radiate into cladding.



# Slab Waveguide — Synopsis



# Slab Waveguide — Group Delay Dispersion (1)

Weakly guiding slab, scalar approximation. Group delay  $t_g$  after  $L$ :

$$t_g/L = d\beta/d\omega = n_{eg}/c, \quad B \approx \frac{\beta - k_2}{k_1 - k_2}, \quad \beta = k_2 + (k_1 - k_2) B,$$

$$\frac{t_g}{L} = \frac{d\beta}{d\omega} = \frac{1}{c} \frac{d\beta}{dk_0} \approx \left\{ \begin{array}{l} \Delta \ll 1 \\ \frac{dV}{dk_0} \approx \frac{V}{k_0}, \quad V = \frac{h}{2} k_0 n_1 \sqrt{2\Delta} \\ n_{1g} - n_{2g} \approx n_1 - n_2 \end{array} \right\} \approx$$

$$\approx \frac{n_{2g}}{c} + \frac{n_{1g} - n_{2g}}{c} B + (k_1 - k_2) \frac{dB}{d\omega} \approx \frac{n_{2g}}{c} + \frac{n_{1g} - n_{2g}}{c} \left( B + k_0 \frac{dB}{dk_0} \right)$$

$$\approx \frac{n_{2g}}{c} + \frac{n_{1g} - n_{2g}}{c} \left( B + k_0 \frac{dB}{dV} \frac{dV}{dk_0} \right) \approx \frac{n_{2g}}{c} + \frac{n_{1g} - n_{2g}}{c} \left( B + k_0 \frac{dB}{dV} \frac{dV}{dk_0} \right)$$

$$\approx \frac{n_{2g}}{c} + \frac{n_{1g} - n_{2g}}{c} \left( B + V \frac{dB}{dV} \right) = \underbrace{\frac{n_{2g}}{c}}_{\text{mat. disp.}} + \underbrace{\frac{n_{1g} - n_{2g}}{c} \frac{d(VB)}{dV}}_{\text{waveguide dispersion}} \quad \text{gr. delay fctr}$$



## Slab Waveguide — Group Delay Dispersion (2)

Length-related group delay difference  $\Delta t_g/L$ , two signals in same mode  $m$  at optical carriers differing by  $\Delta\lambda$ :

$$\Delta t_g/L = [t_g(\lambda + \Delta\lambda, m) - t_g(\lambda, m)] / L = C \Delta\lambda = (M + W) \Delta\lambda,$$

$$M = M_s = \underbrace{\frac{1}{c} \frac{dn_{sg}}{d\lambda}}_{\text{material dispersion}} \quad (s = 1 \text{ or } 2), \quad W = -\frac{n_{1g} - n_{2g}}{c\lambda} V \underbrace{\frac{d^2(VB)}{dV^2}}_{\text{dispersion factor}}$$

In core ( $M_1$ ) and cladding ( $M_2 \approx M_1$ ) assumed to be similar.

Chromatic dispersion first-order  $C$  (unit ps / (km nm)). Second-order dispersion coefficient  $D$  (unit ps / (km nm)<sup>2</sup>),

$$\Delta t_g/L = C \Delta\lambda + D (\Delta\lambda)^2 + \dots, \quad C = \frac{1}{L} \frac{dt_{gm}}{d\lambda}, \quad D = \frac{1}{2L} \frac{d^2 t_{gm}}{d\lambda^2}$$


$C(\lambda_C) = 0$ ,  $\lambda_C$  is zero of  $C(\lambda_C)$  for mode  $m$ .


$$\Delta t_g/L = C_\lambda(\lambda) \Delta\lambda = (C + D \Delta\lambda) \Delta\lambda, \quad D = \frac{dC_\lambda(\lambda)}{d\lambda}$$

Dispersion slope:  $D$



# Slab Waveguide — Dispersion Types

**Intramodal dispersion** Group delay dispersion (or group velocity dispersion, GVD) for a fixed mode  $m$ . Parameters: Chromatic dispersion coefficient  $C = M + W$ , material dispersion coefficient  $M$ , waveguide dispersion coefficient  $W$ , dispersion factor  $V d^2(VB) / dV^2$ , dispersion slope  $D$ . 

**Intermodal dispersion** (or simply modal dispersion) For  $V$  fixed, the slopes of  $B(V) \hat{=} \beta(\omega)$  corresponding to group delay vary between different modes (see zigzag rays ). Short impulse at  $z = 0$  generates series of impulses at  $z = L$ . Spread of group delays between different modes  $m$  and  $m + \Delta m$ ,

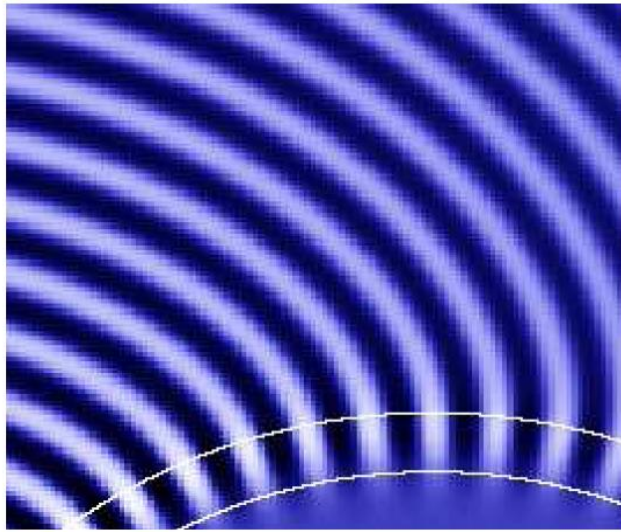
$$\Delta t_g / L = [t_g(\lambda, m + \Delta m) - t_g(\lambda, m)] / L = G \Delta m$$

$G$  is modal dispersion coefficient. For  $\Delta \ll 1$ , maximum spread of allowed zig-zag path angles diminished, and so is the modal dispersion.

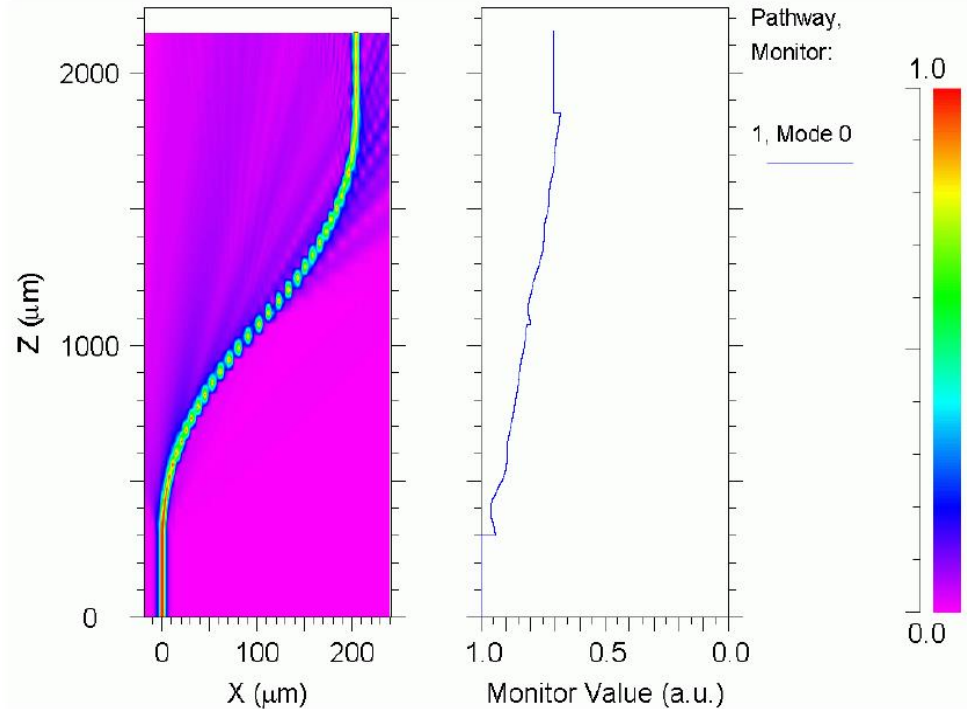




# Slab Waveguide — Bend



(a) Phase fronts for a bent waveguide



(b) Electric field magnitude and waveguide power for an S-bend

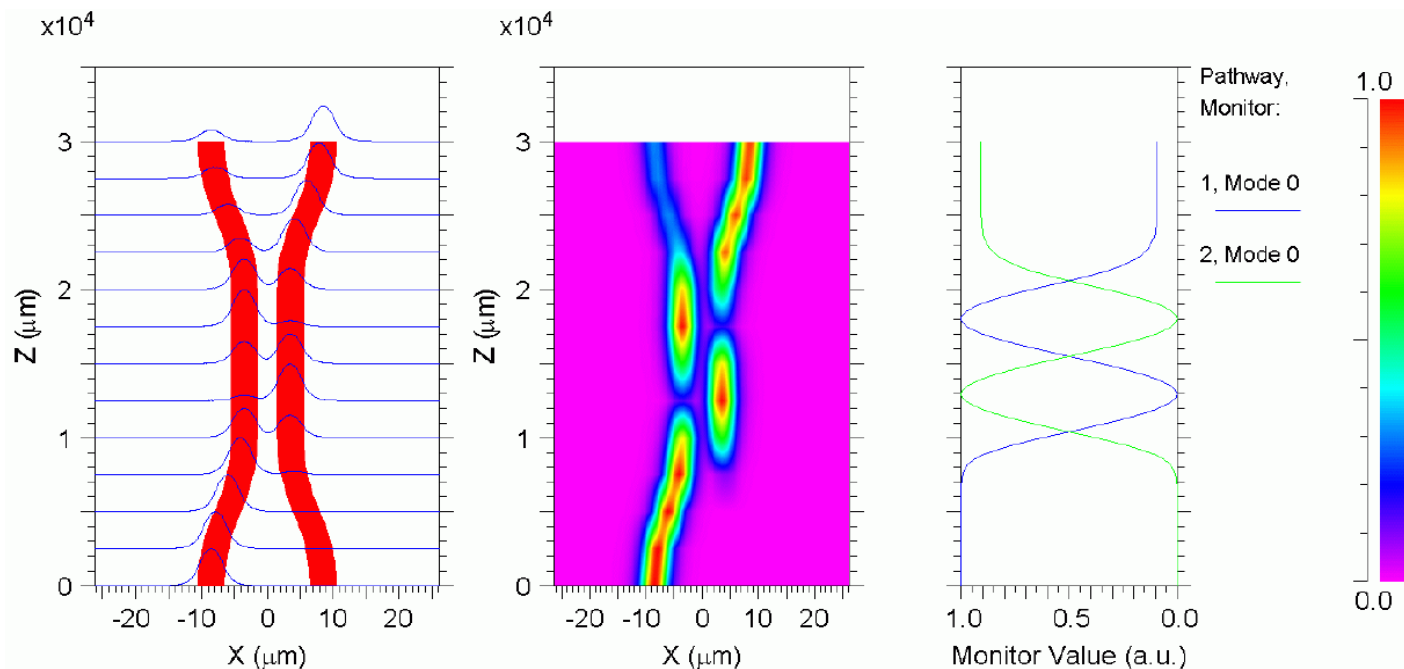
**Fig. 2.10.** Slab waveguide bends in scalar approximation. (a) Phase surfaces for a circular waveguide bend<sup>20</sup> (b) Waveguide height  $h = 5 \mu\text{m}$ , initial and ending straight section lengths  $300 \mu\text{m}$ , bend radii  $3 \text{ mm}$ , angle of oblique section  $15^\circ$ , refractive index difference  $n_1 - n_2 = 0.007$ , cladding refractive index  $n_2 = 1.5$ , vacuum wavelength  $\lambda = 1.55 \mu\text{m}$ . Excitation of fundamental guided mode  $m = 0$  (Fig. 2.8) in straight waveguide at  $z = 0$ . (left) Contour plot of electric field magnitude with colour scale at rightmost side (right) Total power in waveguide cross-section along the waveguide axis (1, Mode 0, blue)



# LECTURE 7



# Slab Waveguide — Directional Coupler



**Fig. 2.11.** Slab waveguide directional coupler in scalar approximation. Waveguide height  $h = 4\ \mu\text{m}$ , separation of inner core-cladding boundaries  $3\ \mu\text{m}$ , refractive index difference  $n_1 - n_2 = 0.0067$ , cladding refractive index  $n_2 = 3.378$ , vacuum wavelength  $\lambda = 1.3\ \mu\text{m}$ . Excitation of fundamental guided mode  $m = 0$  (Fig. 2.8) in straight waveguide at lower left coupler input. Mind the vast scale differences for the  $x$ - and the  $z$ -directions; the curved section is angled only at about  $6^\circ$ . (left) Slice plot of electric field magnitude (middle) Contour plot of electric field magnitude with colour scale at rightmost side (right) Total power in waveguide cross-sections along the axes of left-hand side waveguide (1, Mode 0, blue) and of right-hand side waveguide (2, Mode 0, green)

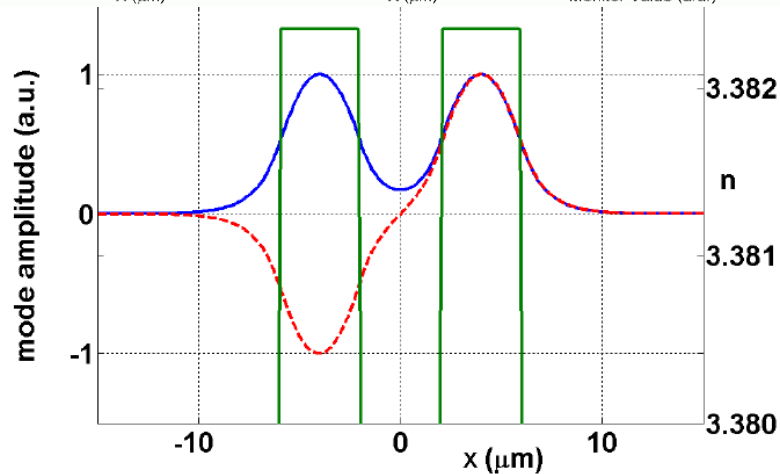
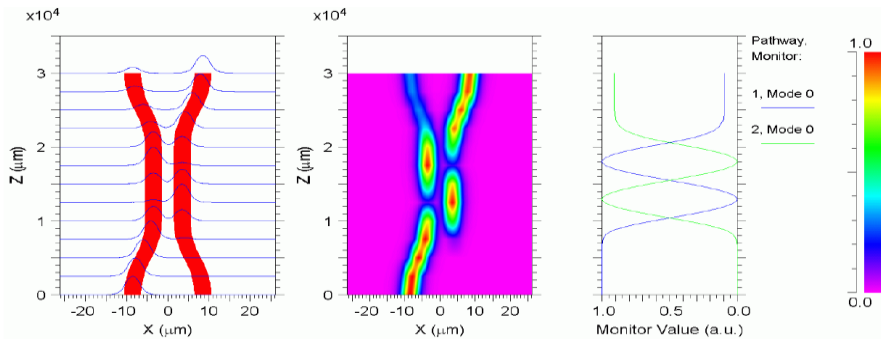
**Analogy:** Double pendulum ( $\omega_0 = \sqrt{K/m}$ , along.  $x$ , rest. force  $Kx$ , mass  $m$ )

**Java control panel (javacpl.exe):** Sicherheit, Hoch (Mindestempfehlung)  $\rightarrow$  Mittel, Anwenden.

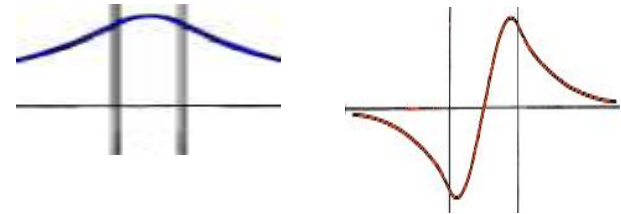
**Run Java.** Then return to original setting: Mittel  $\rightarrow$  Hoch (Mindestempfehlung), OK



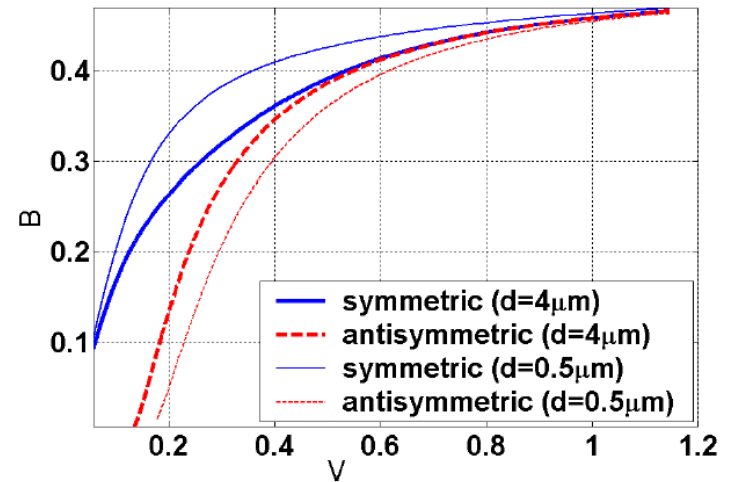
# Slab Waveguide — Directional Coupler. Supermodes (1)



(a) Electric field magnitudes and refractive index



Spatial period **symmetric** mode:  $z_s = \frac{2\pi}{\beta_s} < z_a$   
 Spatial period **antisymmetric** mode:  $z_a = \frac{2\pi}{\beta_a} > z_s$



(b) Dispersion diagrams

**Fig. 2.12.** Directional coupler with two infinitely long parallel slabs. Waveguide height  $h = 4\mu\text{m}$ , separation of inner core-cladding boundaries  $d = 4\mu\text{m}$ , refractive index difference  $n_1 - n_2 = 0.0067$ , cladding refractive index  $n_2 = 3.378$ , vacuum wavelength  $\lambda = 1.3\mu\text{m}$ . Fundamental **symmetric** (blue, —) and next higher-order **antisymmetric** supermode (red, - - -) (a) Electric field magnitudes, and refractive index profile  $n(x)$  (rectangular shapes, green, right-hand side axis) (b) Dispersion diagrams for wider ( $d = 4\mu\text{m}$ , thick lines) and narrower separated waveguides ( $d = 0.5\mu\text{m}$ , thin lines). Normalized frequency  $V = \frac{h}{2} k_0 (n_1^2 - n_2^2)^{1/2}$

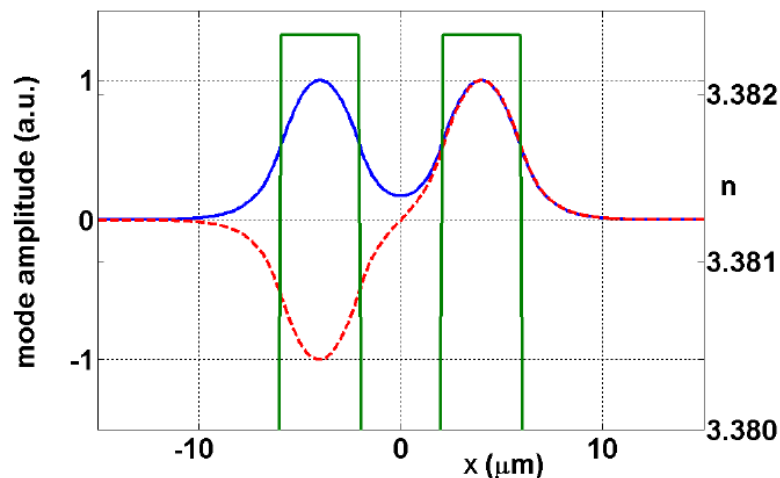


# Slab Waveguide — Directional Coupler. Supermodes (2)

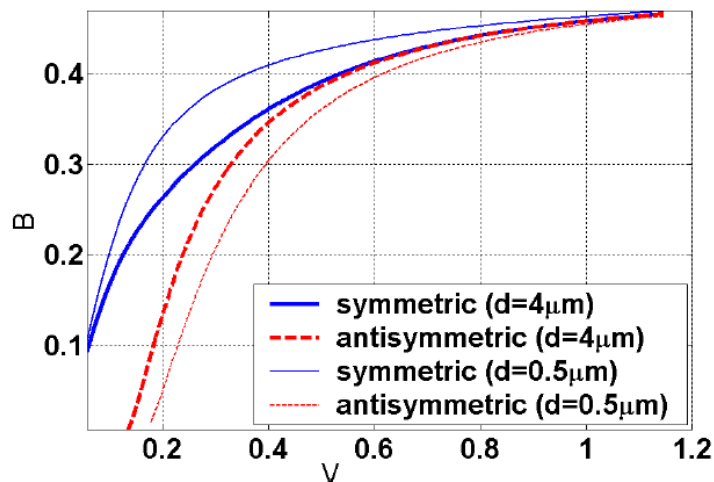
**Symmetric** and **antisymmetric** mode excited with transverse electric field magnitudes  $E_s(x)$  and  $E_a(x)$ . Superposition:

$$E_-(x, z) = E_s(x) e^{-j\beta_s z} - E_a(x) e^{-j\beta_a z},$$

$$E_+(x, z) = E_s(x) e^{-j\beta_s z} + E_a(x) e^{-j\beta_a z}$$



Electric field magnitudes and refractive index



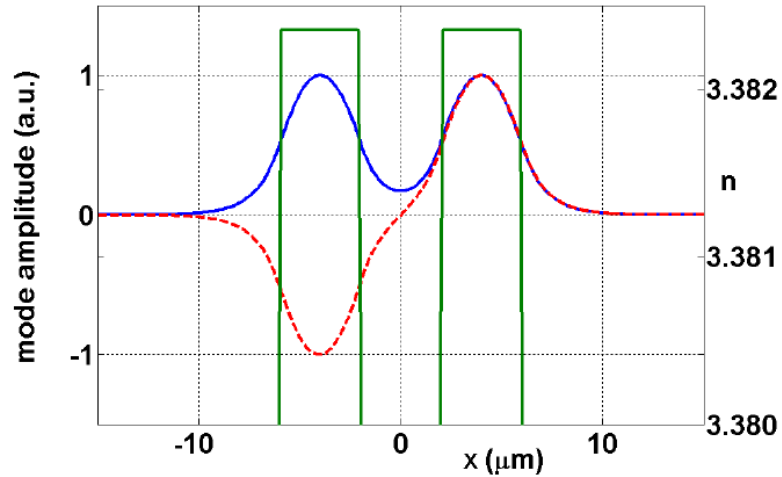
Dispersion diagrams



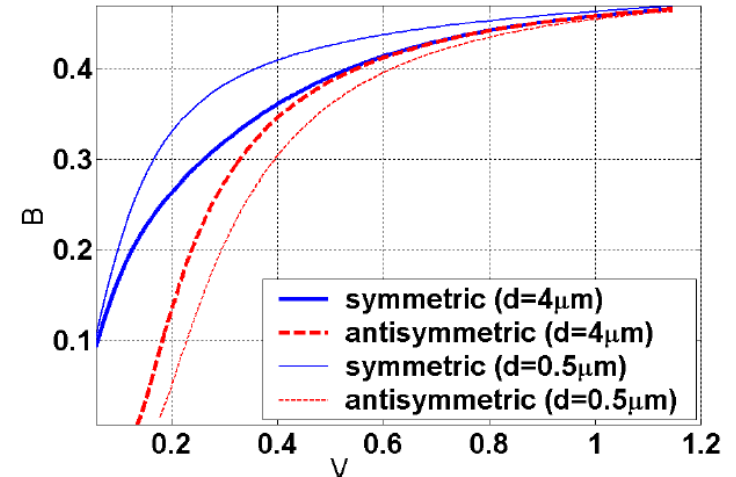
# Slab Waveguide — Directional Coupler. Beat Length (1)

Mode profiles  $E_{s,a}(x)$  very similar. Superposition  $E_-(x, z)$  concentrates virtually all power in left slab.  $E_+(x, z)$  has all power in right slab. Supermodes propagate with different  $v_{s,a} = \omega/\beta_{s,a} \rightarrow$  transverse field shapes  $E_{\mp}(x, z)$  change with  $z$ . If phase difference  $2\pi$ , constellation at  $z = 0$  repeats after beat length ( $n_{e s,a} = \beta_{s,a}/k_0$ ):

$$|\beta_s - \beta_a| \Lambda = 2\pi, \quad \Lambda = \frac{2\pi}{|\beta_s - \beta_a|} = \frac{\lambda}{|n_{e s} - n_{e a}|}$$



Electric field magnitudes and refractive index



Dispersion diagrams

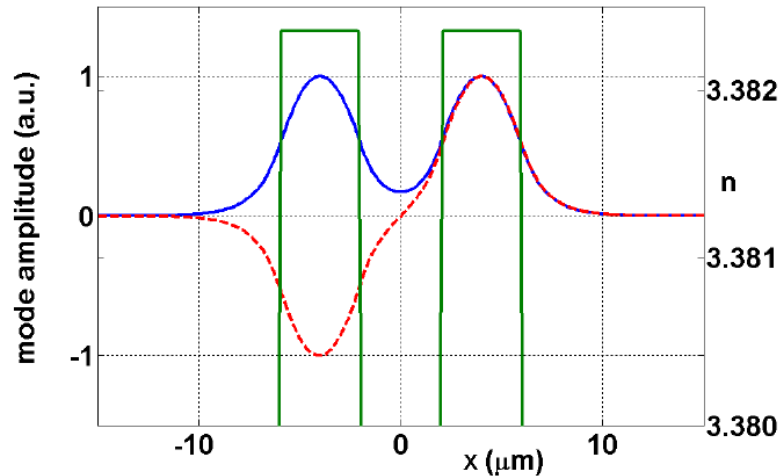




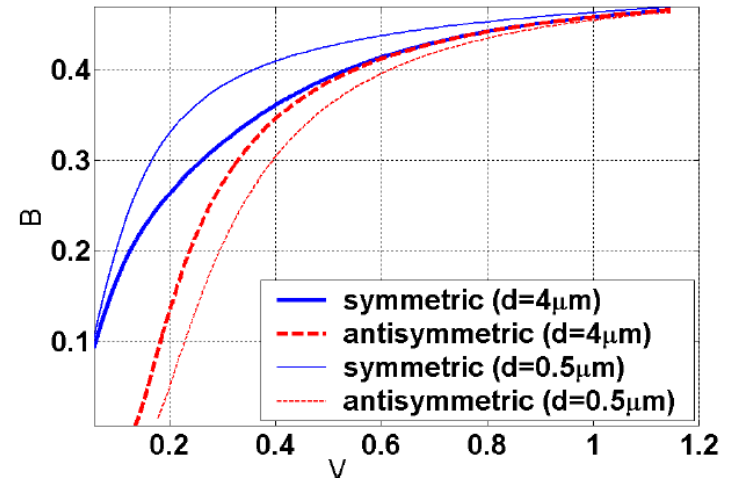
# Slab Waveguide — Directional Coupler. Beat Length (2)

At  $z = \Lambda/2$ , phase shift is  $\pi$ , superposition  $E_-(x, z) \leftrightarrow E_+(x, z)$ . Virtually all power transferred from one waveguide to the other one. The longer  $\Lambda$ , i. e., the longer the interaction between both WG needs to be, the weaker the coupling. Explanation:

If waveguide separation reduced from  $h = 4 \mu\text{m}$  to  $h = 0.5 \mu\text{m}$ , propagation constants  $\beta_{s,a}$  differ more  $\rightarrow \Lambda = 2\pi / |\beta_s - \beta_a|$  reduced.



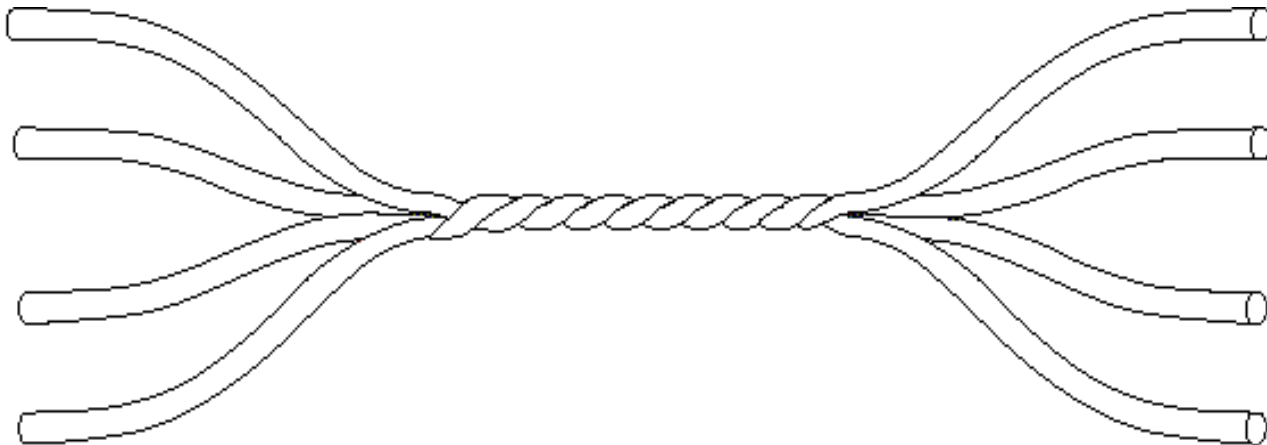
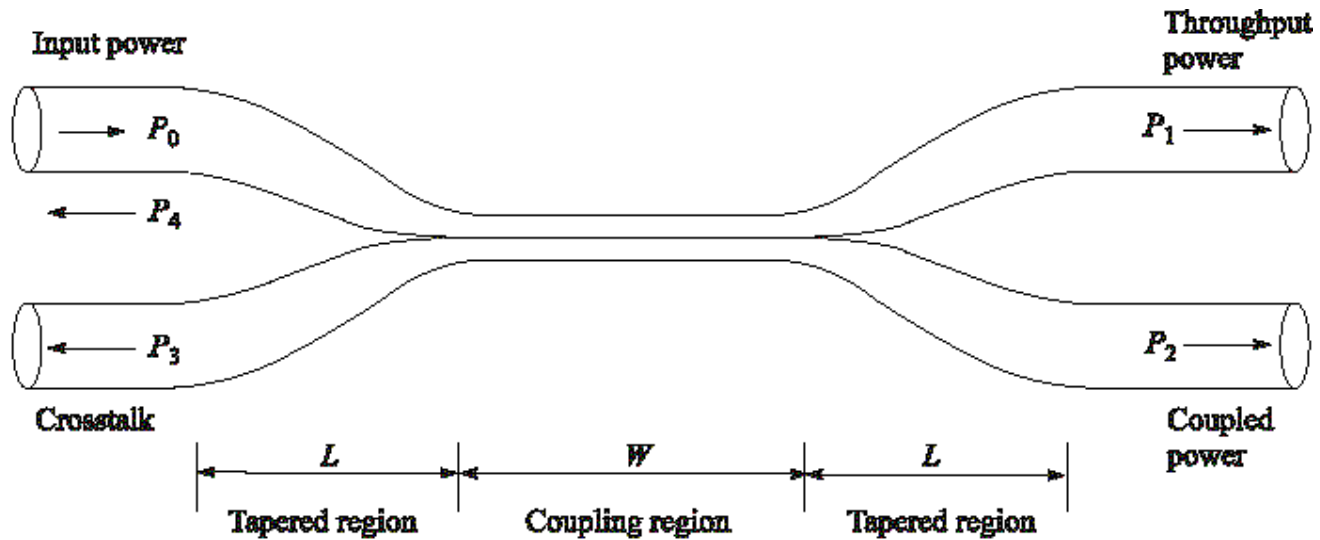
Electric field magnitudes and refractive index



Dispersion diagrams



# Directional Coupler — Fused Fibres. $2 \times 2$ / $4 \times 4$



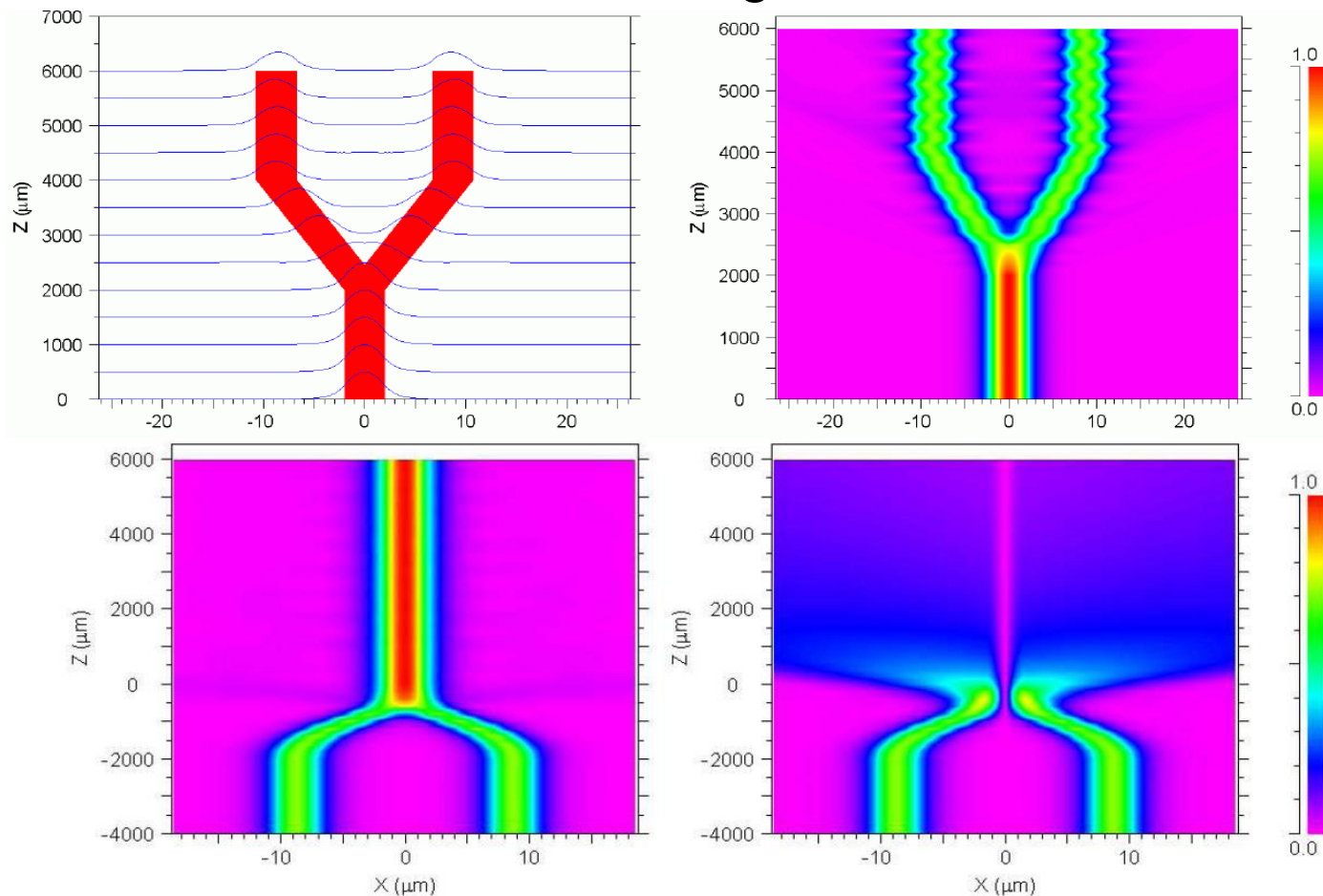
# Directional Coupler — Manufacturing Machinery



Corner Stone's Fiber Coupler Manufacturing Workstation FCMW-2100. <http://www.cornerstone.com.tw> (2005)



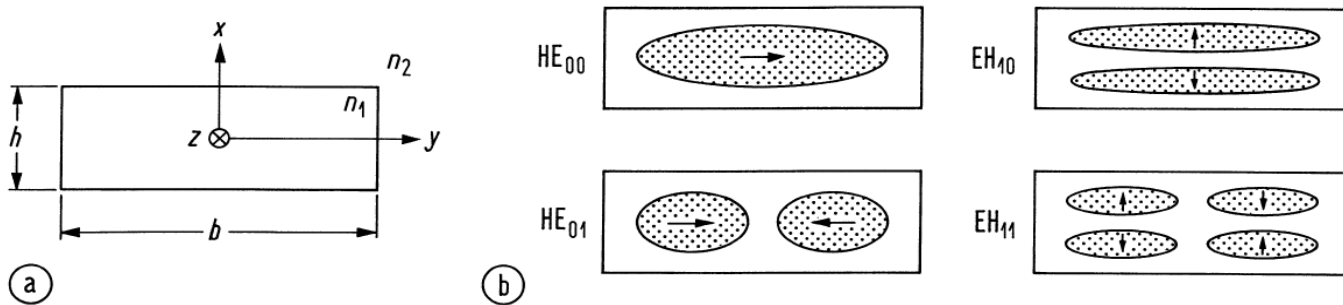
# Slab Waveguide — Y-Branch



**Fig. 2.14.** Slab waveguide Y-branch in scalar approximation. Waveguide height  $h = 3\ \mu\text{m}$ , refractive index difference  $n_1 - n_2 = 0.0067$ , cladding refractive index  $n_2 = 3.378$ , vacuum wavelength  $\lambda = 1.3\ \mu\text{m}$ . Mind the vast scale differences for the  $x$ - and the  $z$ -directions; the branch section is angled at only  $0.25^\circ$ . Contour plot of electric field magnitude with colour scale at rightmost side. (left) Symmetric-mode excitation (right) Antisymmetric-mode excitation



# Strip Waveguide — Symmetric



Cross-section of a buried strip waveguide (a) geometric arrangement (b) transverse electric field and near-field intensity (dotted areas correspond to high intensity)

A lateral phase condition equivalent to the previous vertical phase condition holds. A dispersion equation for  $u_S$  and  $w_S$  (subscript  $S$  like strip) similar to  $w = u \tan u$ ,  $w = -u \cot u$  may be calculated. A second, lateral mode index  $n = 0, 1, 2, \dots$  counts the  $n + 1$  intensity maxima inside the strip along the  $y$ -direction. Slight tilt of  $E_m$ -waves generates  $H$ -component in  $z$ -direction in addition to the already existing  $E$ -component. Modes with longitudinal  $E$ - and  $H$ -components are called hybrid modes or  $EH_{mn}$ -modes. Analogously: Hybrid  $HE_{mn}$ -modes from  $H_m$ -waves of the slab waveguide.



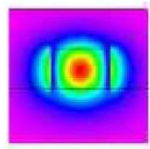
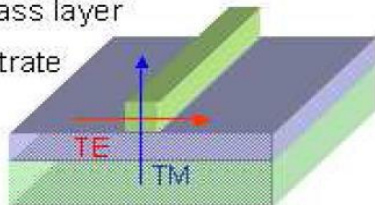


# Strip Waveguide — Asymmetric, Pedestal

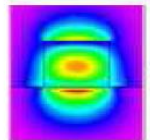
straight  $0.365 \times 0.365 \mu\text{m}^2$  Si WG

thick glass layer

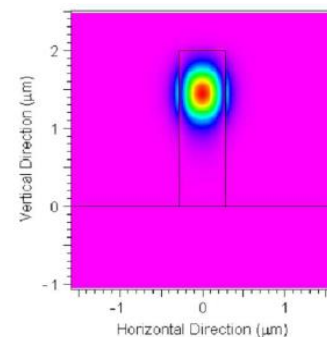
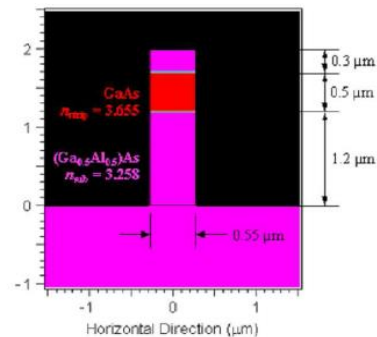
Si substrate



$\text{HE}_{00}$  (quasi TE)

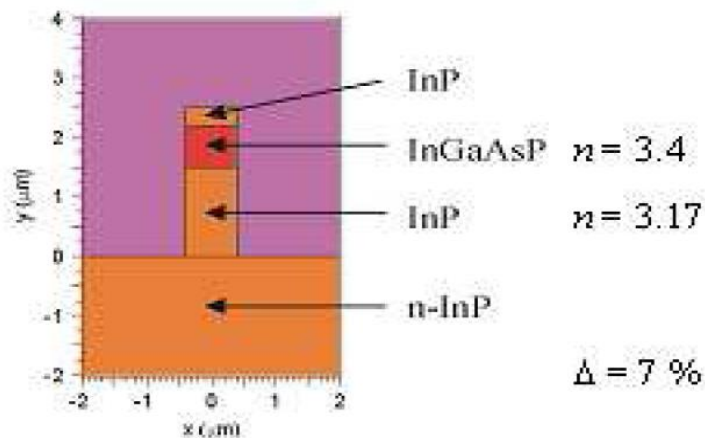


$\text{EH}_{00}$  (quasi TM)

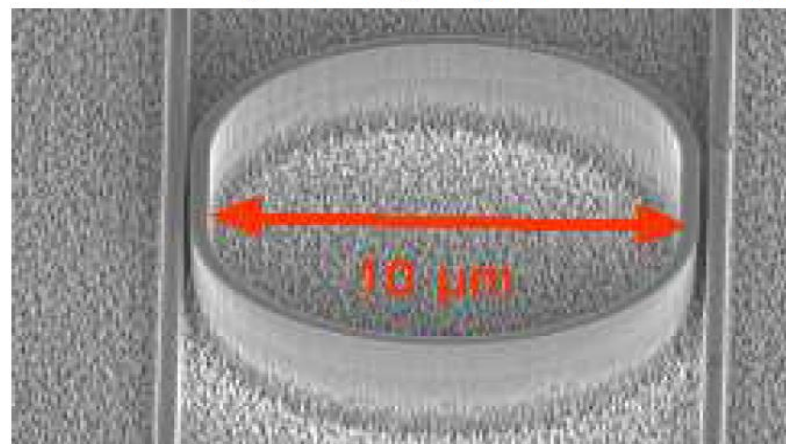


(a) SOI strip waveguide with fundamental mode field magnitudes

(b) GaAs/GaAlAs pedestal waveguide. Left: index profile. Right: quasi-TE field magnitude



(a) InGaAsP/InP pedestal waveguide, refractive index profile



(b) InGaAsP/InP pedestal waveguide, race-track ring filter

**Fig. 2.17.** InGaAsP/InP pedestal waveguide structure (a) Refractive index profile (b) Scanning electron microscope (SEM) picture of race-track ring resonator with two straight bus waveguides. Waveguide widths 400 nm, coupling gaps 100 nm (left) and 200 nm (right). At ring resonances, all power is transferred from one bus to the other. Signals at other frequencies pass unaffected





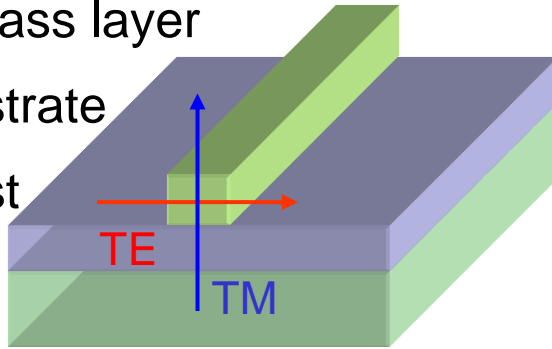
# Strip Waveguide — High-Index Contrast

Straight  $550 \times 400 \text{ nm}^2$  Si WG

thick glass layer

Si substrate

contrast

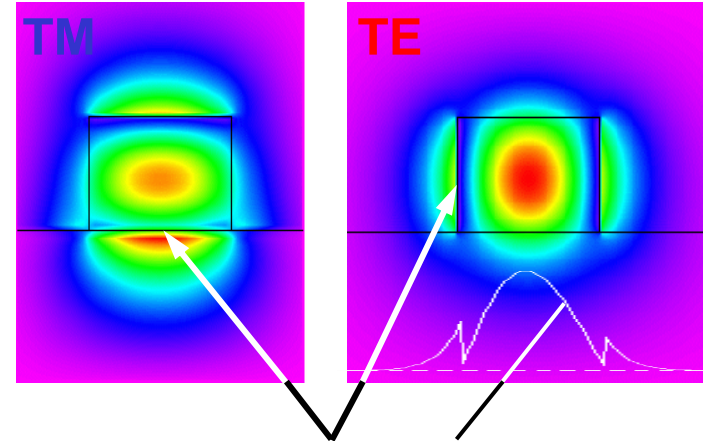


$$n_1 = 3.5$$

$$n_2 = 1.4$$

$$n_3 = 3.5$$

$$\Delta = 60 \%$$



Normal component  $D_n$  of  $\vec{D}(\vec{r})$  continuous:

$$D_n = \epsilon_0 \epsilon_r(\vec{r}) E_n(\vec{r})$$

Single-moded for width  $w \approx \lambda / n_1$ , i.e., ultra-compact **nanostrips**, couplers, bends. Spectral (e.g., resonator) **accuracy**  $\delta\lambda \sim 1.4 \text{ nm} \rightarrow \delta w \sim 1 \text{ nm}$

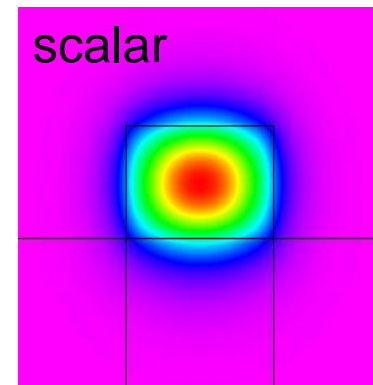
Usual conventional waveguides are weakly guiding:

$$\Delta = (n_1 - n_2) / n_1 = 0.1 \dots 5 \%$$

$$\text{single-moded for width } w \approx 10\lambda / n_1 = 10 \frac{1.5 \mu\text{m}}{1.5} = 10 \mu\text{m}$$

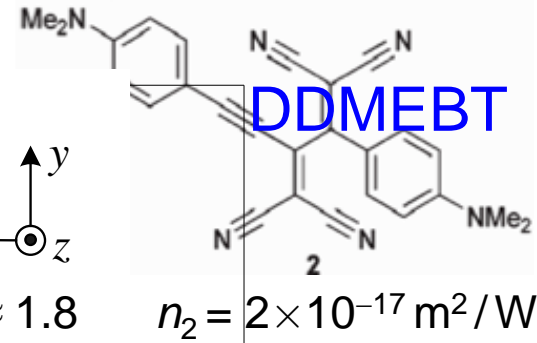
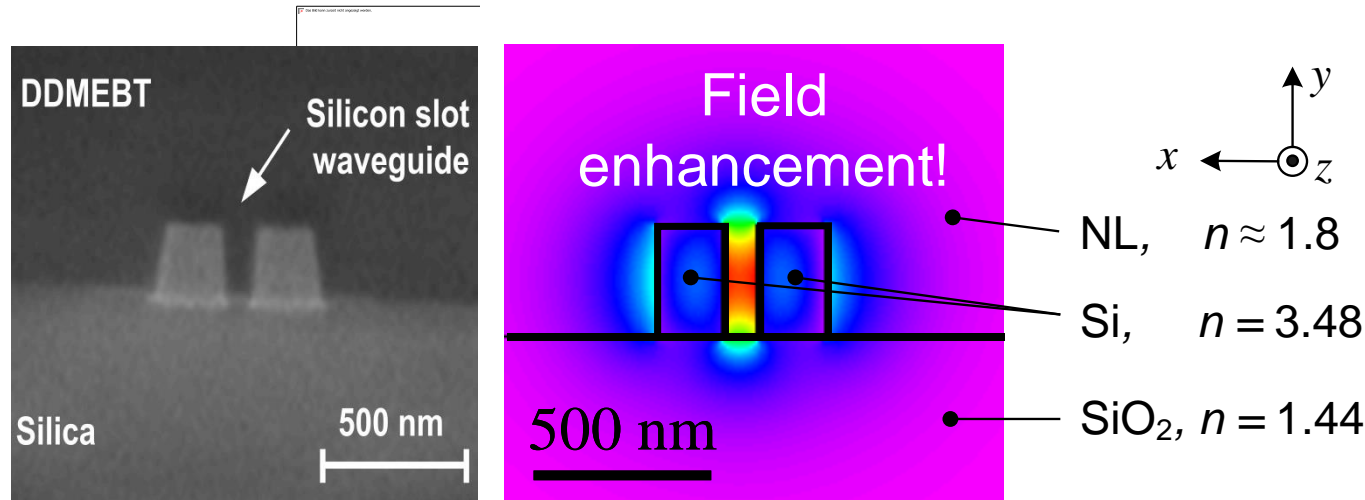
bends and couplers need long, adiabatic transitions

Only for weak guiding, a scalar approximation suffices.



# Silicon-Organic Hybrid Slot Waveguide

Field enhancement in low-index cladding:



$$n_2 = 2 \times 10^{-17} \text{ m}^2/\text{W}$$

Field confinement due to slot geometry:

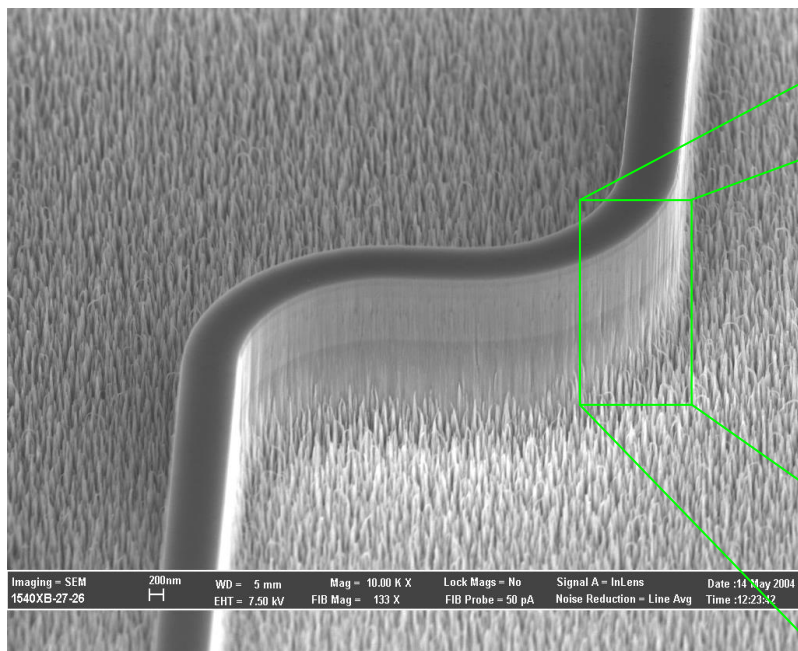
$$A_{\text{eff}}^{(3)} \approx 0.1 \mu\text{m}^2 \text{ for slot width of } 100 \text{ nm}$$

Maximum nonlinearity depends on organic material. Measured:

$$\gamma = \frac{n_2 k_0}{A_{\text{eff}}^{(3)}} \approx 10^5 / (\text{W km}), \quad \text{negligible FCA}$$



# Pedestal Nanostrip — Rough Sidewalls



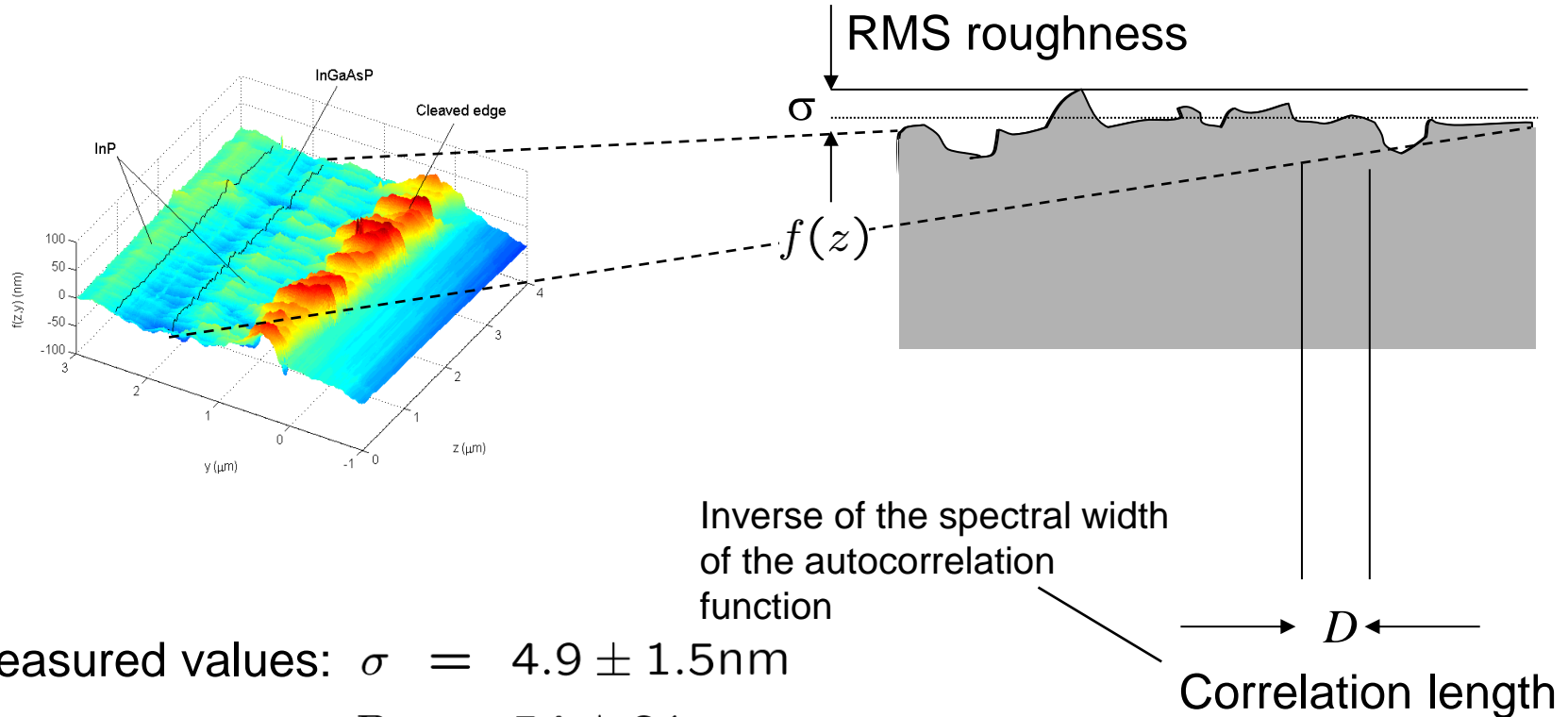
InGaAsP/InP pedestal (1.55  $\mu\text{m}$ ) WG  
 $h = 700$  nm,  $w = 600$  nm (CAIBE,  
 $\text{SiN}_x$ )

Meas. attenuation: 7 dB/mm (TE)  
4 dB/mm (TM)



# Measurement of Surface Roughness

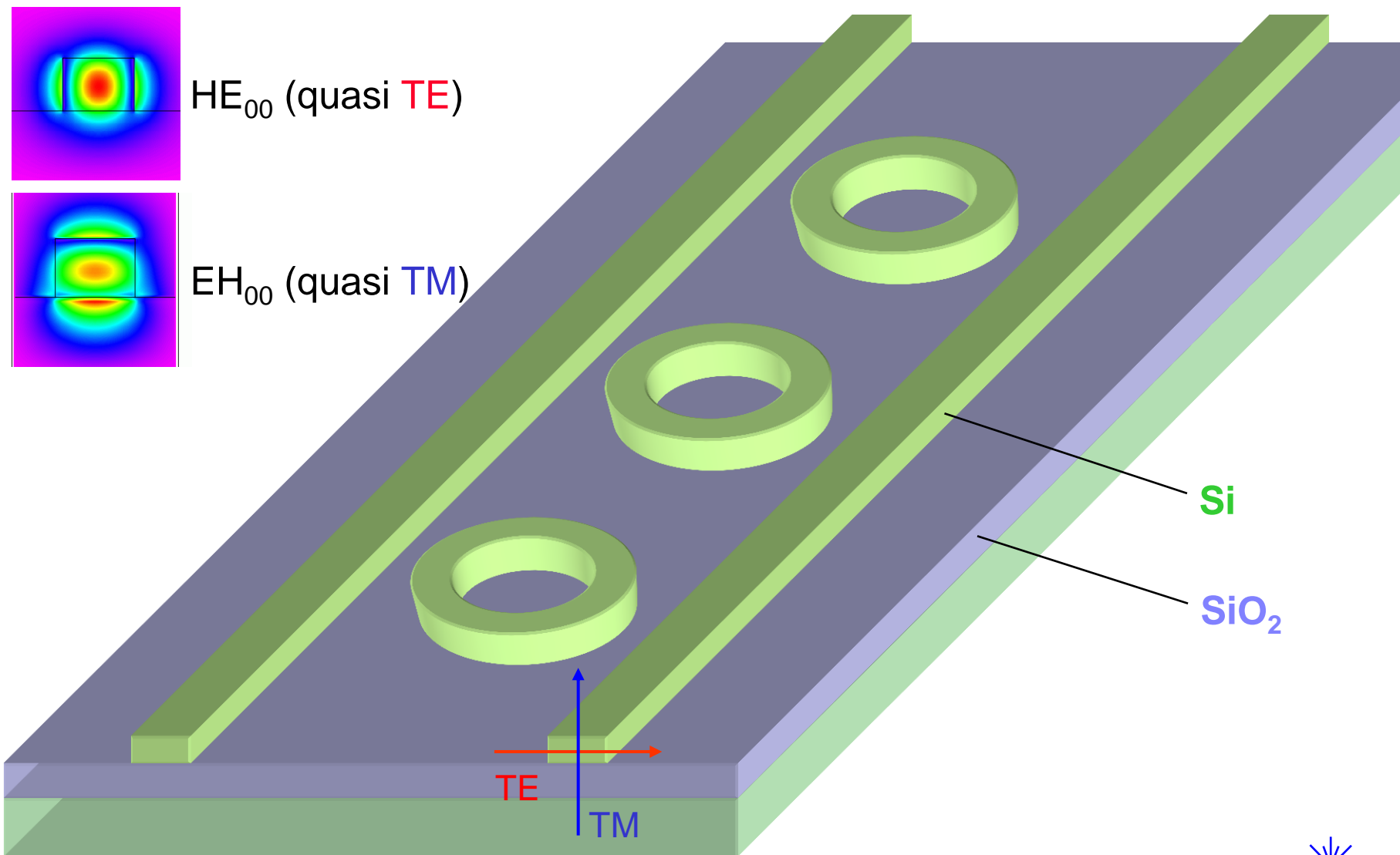
Roughness is vertically chiselled, and so can be described by the parameters  $\sigma$  and  $D$ :



How does the attenuation of the waveguide depend on the RMS roughness and on the correlation length?



# Strip Waveguide — Nanostrips. Versatile Ring Resonator



## Fibre Waveguide — Refractive Index Profile



**Transmission lengths** in the 100...1 000 km range, low production cost, low attenuation (0.2 dB / km), and low group delay dispersion important → quartz glass fibres. For 100 m LAN very inexpensive **plastic optical fibres (POF)** preferable.

**Isotropic, cylindersymmetric core** ( $n_1$ ) / cladding ( $n_2 < n_1$ ),  $2a = 10...100 \mu\text{m}$  /  $2b = 125 \mu\text{m} \rightarrow \infty$ . Cylindrical coordinates  $r, \varphi, z$ . Refractive index profile, relative refractive index difference:



$$n^2(r) = \begin{cases} n_1^2 [1 - 2\Delta g(r/a)], & 0 \leq r < a, \\ n_1^2 [1 - 2\Delta] = n_2^2, & a \leq r < \infty, \end{cases} \quad g(r/a) = \begin{cases} 0, & r = 0 \\ 1, & r \geq a \end{cases}$$

**Profile function**  $g(r/a)$  for power law profiles:

$$g(r/a) = (r/a)^q, \quad 0 \leq q < \infty$$

**Step-index profile** ( $q \rightarrow \infty$ ,  $n = n_1$  for  $0 \leq r < a$ ,  $n = n_2$  for  $r \geq a$ ).

**Parabolic profile**  $q = 2$ . Graded-index profile with  $q$  for minimum intermodal dispersion.

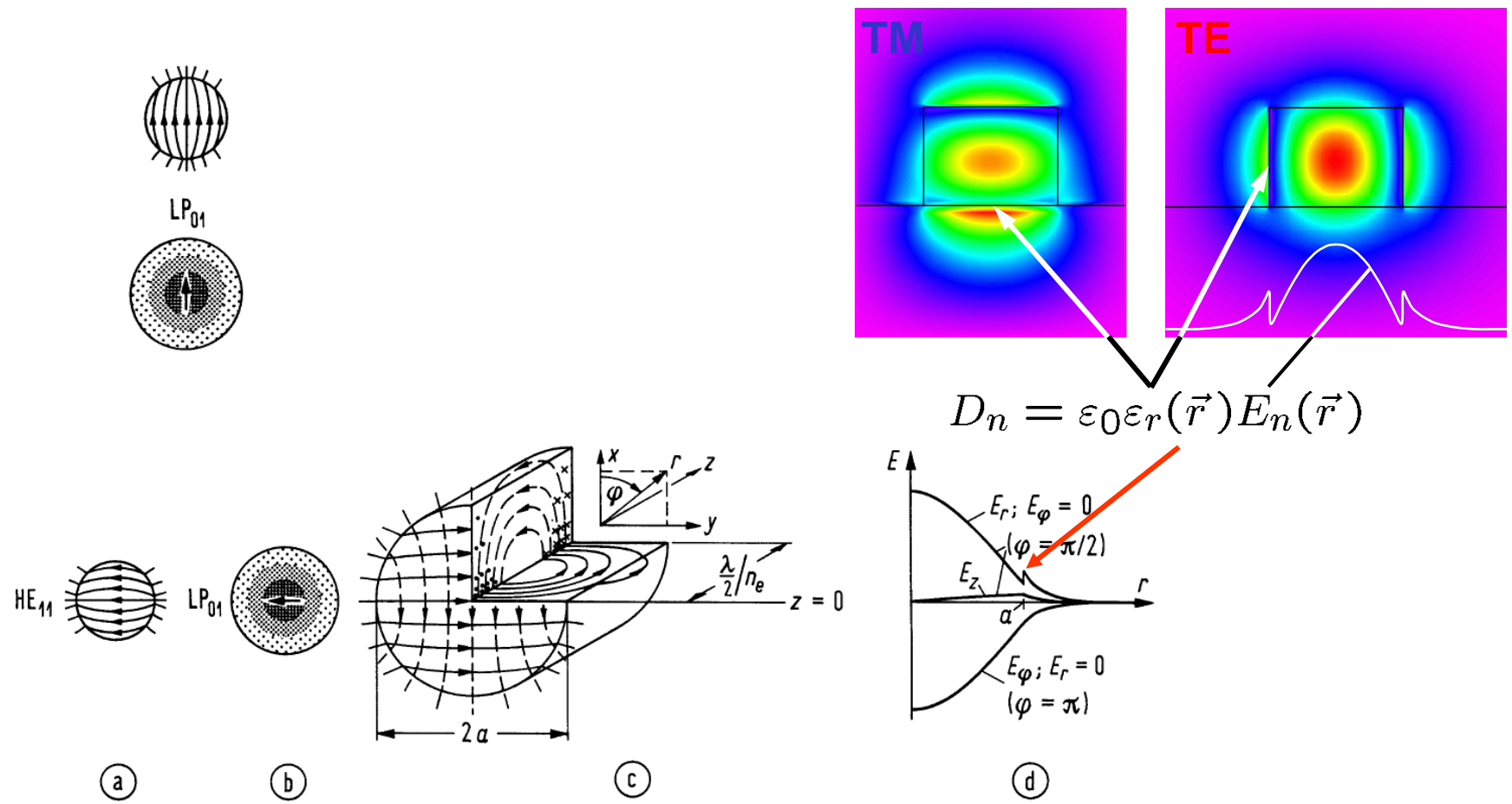




# LECTURE 8



# Step-Index Fibre — Vector Fields (1)

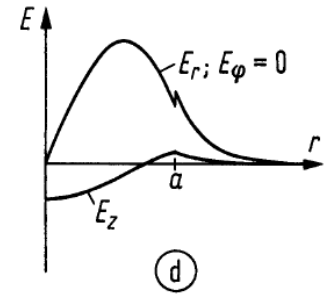
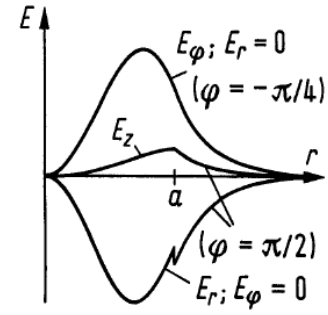
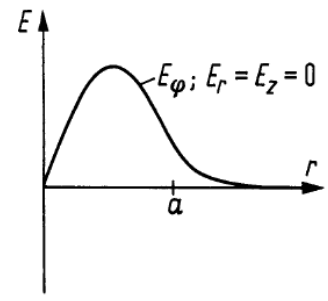
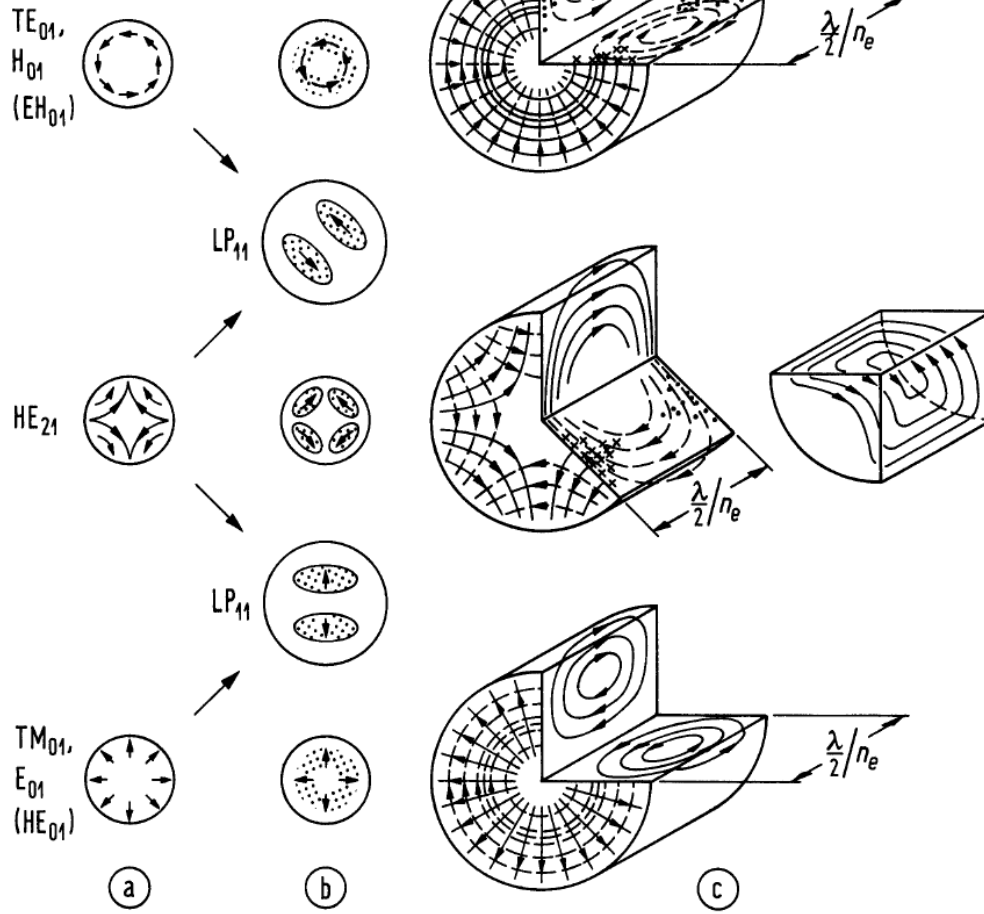


$$D_n = \epsilon_0 \epsilon_r(\vec{r}) E_n(\vec{r})$$

**Fig. 2.19.** Fields in a step-index fibre. Electric field strength (—); magnetic field strength (---); intensity (shaded). (a) electric field of vector modes and (b) electric field and intensity of vector and LP-modes, viewed in  $-z$ -direction (c) graphs of electric and magnetic fields,  $B = 0.9$  (d) radial dependency of electric field strength,  $V = 4.75$ ,  $\Delta = 4\%$ ;  $E_r, E_\varphi$  (depicted in plane  $z = 0$ ) are cophasal to each other and in quadrature to  $E_z$  (depicted in plane  $z = \lambda/(4n_e)$ )



# Step-Index Fibre



# Fields (2)

Prop. const.  
 $HE_{\nu+1,\mu} - H_{0\mu}$ ,  
 $E_{0\mu} - EH_{\nu-1,\mu}$   
 differ by  $\Delta\beta$ ,  
 beat length  $\Lambda$ , LP-modes

rotate: ◀

$$\Lambda = \frac{2\pi}{\Delta\beta} = \frac{\lambda}{n_e} \frac{\beta}{\Delta\beta}$$

If  $V \gg V_{\nu\mu G}$ ,  
 $\Delta\beta$  de-,  $\Lambda$   
 increases, see  
 slab. ◀

**Fig. 2.19.** Fields in a step-index fibre. Electric field strength (—); magnetic field strength (---); intensity (shaded). (a) electric field of vector modes and (b) electric field and intensity of vector and LP-modes, viewed in  $-z$ -direction (c) graphs of electric and magnetic fields,  $B = 0.9$  (d) radial dependency of electric field strength,  $V = 4.75$ ,  $\Delta = 4\%$ ;  $E_r, E_\phi$  (depicted in plane  $z = 0$ ) are cophasal to each other and in quadrature to  $E_z$  (depicted in plane  $z = \lambda/(4n_e)$ )



## LP<sub>νμ</sub> Modes (1)

Weak guidance  $\Delta \ll 1 \rightarrow$  LP<sub>νμ</sub>, scalar Helmholtz equation, cylindrical coordinates  $\vec{r} = (r, \varphi, z)$ :

$$\Psi(t, \vec{r}) = \Psi(\vec{r}) e^{j\omega t}, \quad (\nabla^2 + k_0^2 n^2(\vec{r})) \Psi(\vec{r}) = 0$$

Separation ansatz,  $\Psi(\vec{r}) = \Psi(r, \varphi, z) = \Psi(r) \Psi(\varphi) \exp(-j\beta z)$ :

$$\left( \frac{1}{r} \frac{\partial}{\partial r} \left( r \frac{\partial}{\partial r} \right) + \frac{1}{r^2} \frac{\partial^2}{\partial \varphi^2} + (-j\beta)^2 + k_0^2 n^2(r) \right) \Psi(r) \Psi(\varphi) = 0,$$

$$\frac{1}{r} \frac{\partial}{\partial r} \left( r \frac{\partial \Psi(r)}{\partial r} \right) \Psi(\varphi) + \frac{1}{r^2} \frac{\partial^2 \Psi(\varphi)}{\partial \varphi^2} \Psi(r) + (k_0^2 n^2(r) - \beta^2) \Psi(r) \Psi(\varphi) = 0,$$

$$r \left( 1 \cdot \frac{\partial \Psi(r)}{\partial r} + r \frac{\partial^2 \Psi(r)}{\partial r^2} \right) \frac{1}{\Psi(r)} + r^2 (k_0^2 n^2(r) - \beta^2) = C_r^2(r), \quad \left| \cdot \frac{\Psi(r)}{r^2} \right.$$

$$\frac{\partial^2 \Psi(\varphi)}{\partial \varphi^2} \frac{1}{\Psi(\varphi)} = C_\varphi^2(\varphi), \quad C_r^2(r) = -C_\varphi^2(\varphi) = C^2 = \text{const}_{r,\varphi} \quad \left| \cdot \Psi(\varphi) \right.$$



## LP<sub>νμ</sub> Modes (2)

Separation constant  $C^2 = \text{const}_{r,\varphi}$ :

$$\frac{\partial^2 \Psi(r)}{\partial r^2} + \frac{1}{r} \frac{\partial \Psi(r)}{\partial r} + (k_0^2 n^2(r) - \beta^2) \Psi(r) = \overbrace{\frac{C^2}{r^2}}^{k_\varphi^2(r)} \Psi(r),$$

$$\frac{\partial^2 \Psi(\varphi)}{\partial \varphi^2} + \overbrace{r^2 k_\varphi^2(r)}^{C^2} \Psi(\varphi) = 0, \quad \Psi(\varphi) = \begin{cases} \cos(C \varphi) \\ \sin(C \varphi) \end{cases}$$

$$\frac{\partial \Psi(\varphi)}{\partial \varphi} = C \begin{cases} -\sin(C \varphi) \\ \cos(C \varphi) \end{cases}, \quad \frac{\partial^2 \Psi(\varphi)}{\partial \varphi^2} = C^2 \begin{cases} -\cos(C \varphi) \\ -\sin(C \varphi) \end{cases},$$

Azimuthal resonance:  $C = \nu$ ,  $\nu = 0, 1, 2, \dots$ ,  $-2\pi r |k_\varphi| = -\nu \cdot 2\pi$

Propagation vector of locally plane wave in weakly inhomogeneous medium:

$$\vec{k} = k_r \vec{e}_r + k_\varphi \vec{e}_\varphi + k_z \vec{e}_z, \quad |k_\varphi(r)| = \frac{\nu}{r}, \quad k_z = \beta,$$

$$|\vec{k}|^2 = k^2 = k_0^2 n^2(r) = k_r^2 + k_\varphi^2 + \beta^2$$



# Weakly Guiding Fibre — Orthonormality and Radial Equation



Radial differential equation (primes on functions mean derivatives wrt argument):

$$\Psi''(r) + \frac{1}{r} \Psi'(r) + k_r^2(r) \Psi(r) = 0, \quad \Psi(r) \equiv \Psi_\mu^{(\nu)}(r),$$
$$k_r^2(r) = k_0^2 n^2(r) - k_\varphi^2 - \beta^2, \quad |k_\varphi| = \nu/r$$

Longitudinal and azimuthal solution, orthonormality:

$$\Psi_{\nu\mu}(r, \varphi, z) = \Psi_{\nu\mu}(r, \varphi) e^{-j\beta_{\nu\mu}z}, \quad \nu, \nu' = 0, 1, \dots, \quad \mu, \mu' = 1, 2, \dots,$$
$$\Psi_{\nu\mu}(r, \varphi) = \Psi_\mu^{(\nu)}(r) \Psi^{(\nu)}(\varphi), \quad \Psi^{(\nu)}(\varphi) = \frac{1}{\sqrt{1+\delta_{\nu 0}}} \begin{cases} \cos \nu\varphi \\ \text{or} \\ \sin \nu\varphi \end{cases},$$

$$n_1 \int_{\varphi=0}^{2\pi} \int_{r=0}^{\infty} \Psi_{\nu\mu}(r, \varphi) \Psi_{\nu'\mu'}(r, \varphi) r \, dr \, d\varphi = \delta_{\nu\nu'} \delta_{\mu\mu'},$$

Intensity:  $I_{\nu\mu}(r, \varphi) = \frac{1}{2} n_1 |\Psi_{\nu\mu}(r, \varphi)|^2$





# LP<sub>νμ</sub> Modes — Step-index Profile. (Modified) Bessel Functions

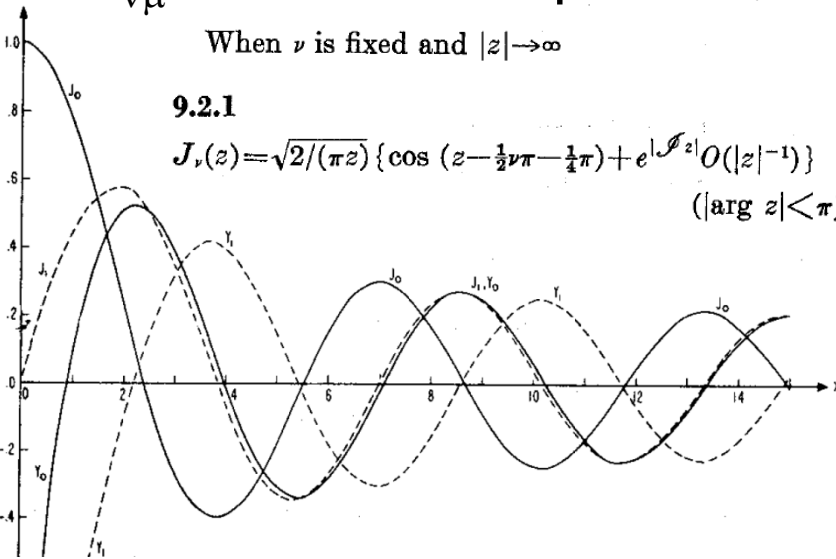
When  $\nu$  is fixed and  $|z| \rightarrow \infty$

**9.2.1**

$$J_\nu(z) = \sqrt{2/(\pi z)} \left\{ \cos\left(z - \frac{1}{2}\nu\pi - \frac{1}{4}\pi\right) + e^{i\mathcal{I}z} O(|z|^{-1}) \right\} \quad (|\arg z| < \pi)$$

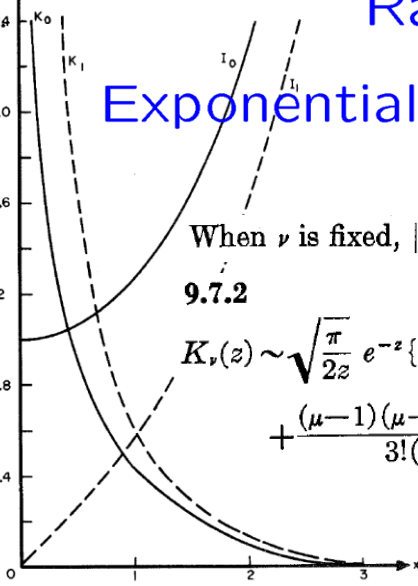
ZEROS AND ASSOCIATED VALUES OF BESSEL FUNCTIONS AND THEIR DERIVAT

$s$	$j_{0,s}$	$J'_0(j_{0,s})$	$j_{1,s}$	$J'_1(j_{1,s})$	$j_{2,s}$	$J'_2(j_{2,s})$
1	2.40482	55577	-0.51914	74973	3.83171	-0.40276
2	5.52007	81103	+0.34026	48065	7.01559	+0.30012
3	8.65372	79129	-0.27145	22999	10.17347	-0.24970
4	11.79153	44391	+0.23245	98314	13.32369	+0.21836
5	14.93091	77086	-0.20654	64331	16.47063	-0.19647
6	18.07106	39679	+0.18772	88030	19.61586	+0.18006
7	21.21163	66299	-0.17326	58942	22.76008	-0.16718
8	24.35247	15308	+0.16170	15507	25.90367	+0.15672
9	27.49347	91320	-0.15218	12138	29.04683	-0.14801
10	30.63460	64684	+0.14416	59777	32.18968	+0.14061
11	33.77582	02136	-0.13729	69434	35.33231	-0.13421
12	36.91709	83537	+0.13132	46267	38.47477	-0.12862
13	40.05842	57646	-0.12606	94971	41.61709	-0.12367
14	43.19979	17132	+0.12139	86248	44.75932	+0.11925
15	46.34118	83717	-0.11721	11989	47.90146	-0.11527
16	49.48260	98974	+0.11342	91926	51.04354	+0.11167
17	52.62405	18411	-0.10999	11430	54.18555	-0.10839
18	55.76551	07550	+0.10684	78883	57.32753	+0.10537
19	58.90698	39261	-0.10395	95729	60.46946	-0.10260
20	62.04846	91902	+0.10129	34989	63.61136	+0.10004
21	65.18994	43533	-0.09886	61893	66.75329	-0.09747
22	68.33141	15084	+0.09675	88807	69.89522	+0.09546
23	71.47288	56635	-0.09480	115721	73.03715	-0.09403
24	74.61435	17186	+0.09299	142635	76.17908	+0.09318
25	77.75582	67737	-0.09132	169549	79.32101	-0.09190
26	80.89729	28288	+0.08979	196463	82.46294	+0.09027
27	84.03876	88789	-0.08838	223377	85.60487	-0.08928
28	87.18023	39290	+0.08708	250291	88.74680	+0.08843
29	90.32170	99791	-0.08588	277205	91.88873	-0.08772
30	93.46317	60292	+0.08478	304119	95.03066	+0.08715



Radially standing wave in core  $J_\nu(u_{\nu\mu} \frac{r}{a})$

Exponentially decaying wave in cladding  $K_\nu(w_{\nu\mu} \frac{r}{a})$



When  $\nu$  is fixed,  $|z|$  is large and  $\mu = 4\nu^2$

**9.7.2**

$$K_\nu(z) \sim \sqrt{\frac{\pi}{2z}} e^{-z} \left\{ 1 + \frac{\mu-1}{8z} + \frac{(\mu-1)(\mu-9)}{2!(8z)^2} + \frac{(\mu-1)(\mu-9)(\mu-25)}{3!(8z)^3} + \dots \right\} \quad (|\arg z| < \frac{3}{2}\pi)$$

Abramowitz, M.; Stegun, I. A. (Eds.): Handbook of mathematical functions, 9. Ed.. New York: Dover Publications 1970

Here for Gauss-Laguerre modes in parabolic-index fibre. However, structure for step-index fibre (but not size!) is essentially the same.

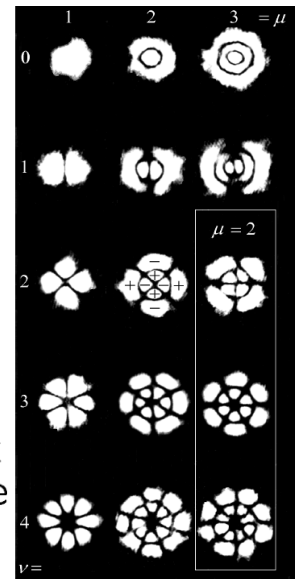


Fig. 2.22. Gauss-Laguerre



# Weakly Guiding Fibre — Notation

In analogy to slab waveguide, define core parameter  $u$ , cladding parameter  $w$  (also expressed by cladding penetration depth  $r_w$ ), normalized frequency  $V$ , relative refractive index difference  $\Delta$ ,  $\kappa$  (an abbreviation for a combination of modified Bessel functions  $K_\nu$  of order  $\nu$ ), normalized propagation constants  $B, \delta$ :

$$u = a\sqrt{k_1^2 - \beta^2}, \quad w = a\sqrt{\beta^2 - k_2^2} = 2a/r_w,$$

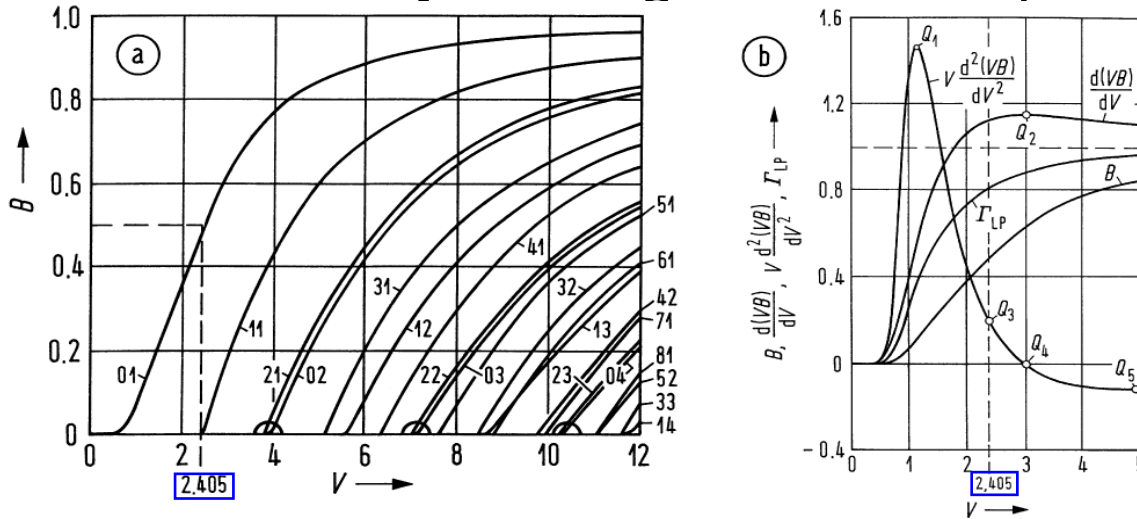
$$V = ak_0 A_N = \sqrt{u^2 + w^2}, \quad A_N = \sqrt{n_1^2 - n_2^2} = n_1\sqrt{2\Delta},$$

$$\kappa(w) = K_\nu^2(w) / [K_{\nu-1}(w) K_{\nu+1}(w)], \quad \beta^2 = k_1^2(1 - 2\delta),$$

$$B = \frac{\beta^2 - k_2^2}{k_1^2 - k_2^2} = \frac{w^2}{V^2} = 1 - \frac{u^2}{V^2} = 1 - \frac{\delta}{\Delta} \approx \{\Delta \ll 1\} \approx \frac{\beta - k_2}{k_1 - k_2}$$



# Weakly Guiding Fibre — Step-Index Profile (1)



Propagation of  $LP_{\nu\mu}$ -modes in a step-index fibre. (a) Normalized propagation constant  $B$ ; cutoff frequencies  $V_{0\mu G} = V_{2,\mu-1,G}$  for  $\mu \geq 2$  marked by semicircles,  $V_{11G} = 2.405$ ,  $V_{21G} = V_{01G} = 3.832$  (b) fundamental mode mode  $LP_{01}$ : normalized propagation constant  $B$ , group delay factor  $d(VB)/dV$ , dispersion factor  $V d^2(VB)/dV^2$ , and field confinement factor  $\Gamma_{LP}$ .  $Q_1 = (1.15, 1.46)$ ,  $Q_2 = (3, 1.14)$ ,  $Q_3 = (2.405, 0.2)$ ,  $Q_4 = (3.04, 0)$ ,  $Q_5 = (4.95, -0.113)$

gr. delay fctr

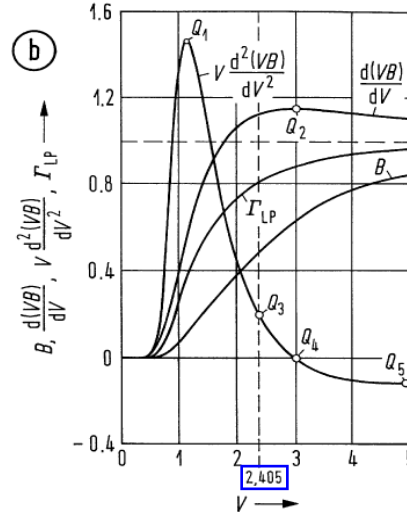
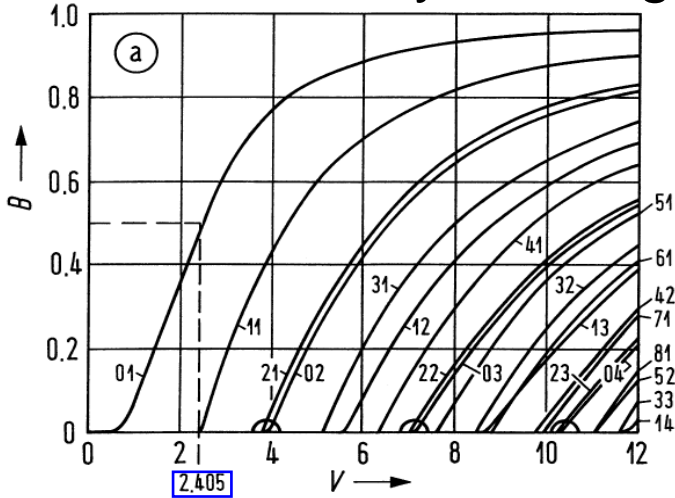
$$\frac{t_g}{L} = \underbrace{\frac{n_{2g}}{c}}_{\text{mat. disp.}} + \underbrace{\frac{n_{1g} - n_{2g}}{c} \frac{d(VB)}{dV}}_{\text{waveguide dispersion}}, \quad \frac{\Delta t_g}{L} = \frac{t_{g,\lambda+\Delta\lambda} - t_{g,\lambda}}{L} = C \Delta\lambda = (M + W) \Delta\lambda,$$

$$M = M_s = \underbrace{\frac{1}{c} \frac{dn_{sg}}{d\lambda}}_{\text{material dispersion}} \quad (s = 1 \text{ or } 2),$$

$$W = -\frac{n_{1g} - n_{2g}}{c\lambda} \underbrace{V \frac{d^2(VB)}{dV^2}}_{\text{dispersion factor}}$$



# Weakly Guiding Fibre — Step-Index Profile (2)



Each pair  $(\nu, \mu)$  stands for 4  $LP_{\nu\mu}$ -modes or 4 guided vector modes:

$$M_g \approx \frac{V^2}{2}, \quad V \gg 1 \quad \blacktriangleleft$$

Sign. near-field ext.:  $\blacktriangleleft$

$$r_M \geq 1.6 a$$

$$\frac{\Delta t_{g \max}}{L} \approx \frac{n_1 - n_2}{c} = \frac{n_1}{c} \Delta$$



gr. delay fctr

$$\frac{t_g}{L} = \underbrace{\frac{n_{2g}}{c}}_{\text{mat. disp.}} + \underbrace{\frac{n_{1g} - n_{2g}}{c} \frac{d(VB)}{dV}}_{\text{waveguide dispersion}},$$

$$\frac{\Delta t_g}{L} = \frac{t_{g, \lambda + \Delta \lambda} - t_{g, \lambda}}{L} = C \Delta \lambda = (M + W) \Delta \lambda,$$

$$M = M_s = \underbrace{\frac{1}{c} \frac{dn_{sg}}{d\lambda}}_{\text{material dispersion}} \quad (s = 1 \text{ or } 2),$$

$$W = -\frac{n_{1g} - n_{2g}}{c\lambda} \underbrace{V \frac{d^2(VB)}{dV^2}}_{\text{dispersion factor}}$$



# Step-Index Fibre — Conventional and Dispersion Shifted

$\lambda / \mu\text{m}$	1.1	1.3	1.56
$V = ak_0 A_N$	2.497	2.113	1.761
$V d^2(VB) / dV^2$	0.150	0.370	0.710
$M / \frac{\text{ps}}{\text{km nm}}$	-23.18	+1.58	+21.93
$W / \frac{\text{ps}}{\text{km nm}}$	-1.78	-3.72	-5.94
$C / \frac{\text{ps}}{\text{km nm}}$	-24.96	-2.14	+15.99
$D(\lambda_C = 1.325 \mu\text{m}) = 0.0415 \text{ ps} / (\text{km nm}^2)$			

**Table 2.1.** Dispersion characteristics<sup>25</sup> of a step-index CSF with  $n_1 = 1.450840$ ,  $n_2 = 1.446918$ ,  $a = 4.1 \mu\text{m}$  and  $\Delta = 0.27\%$ . Wavelength of zero chromatic dispersion  $C(\lambda_C) = 0$  is  $\lambda_C = 1.325 \mu\text{m}$ , cutoff at  $\lambda_{11G} = 1.142 \mu\text{m}$

$\lambda / \mu\text{m}$	1.1	1.3	1.56
$V = ak_0 n_1 \sqrt{2\Delta}$	2.346	1.985	1.654
$V d^2(VB) / dV^2$	0.223	0.476	0.845
$M / \frac{\text{ps}}{\text{km nm}}$	-25.04	+0.58	+21.5
$W / \frac{\text{ps}}{\text{km nm}}$	-7.33	-13.24	-19.59
$C / \frac{\text{ps}}{\text{km nm}}$	-32.37	-12.65	+1.94
$D(\lambda_C = 1.523 \mu\text{m}) = 0.024 \text{ ps} / (\text{km nm}^2)$			

$$-\frac{n_{1g} - n_{2g}}{c\lambda} V \underbrace{\frac{d^2(VB)}{dV^2}}_{\text{dispersion factor}} =$$



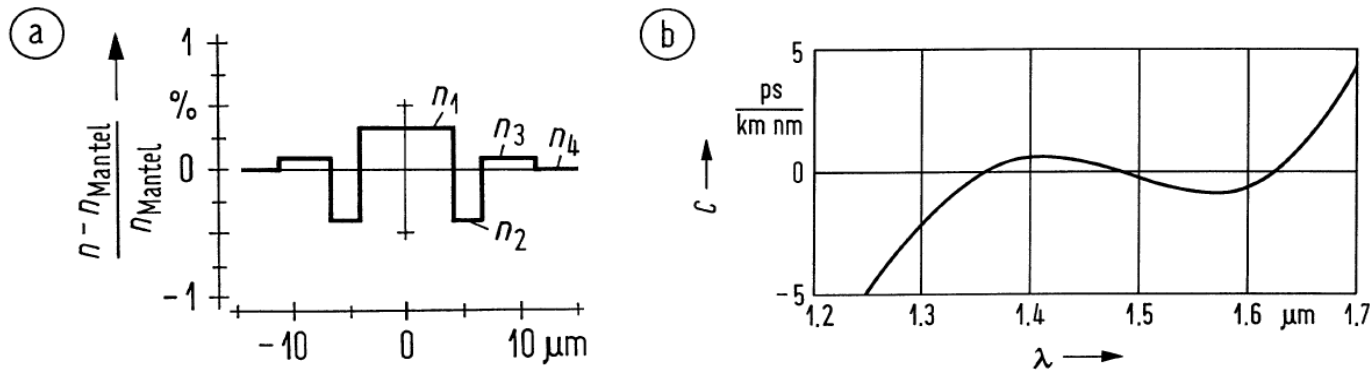
**Table 2.2.** Dispersion characteristics<sup>26</sup> of a step-index DSF with  $n_1 = 1.457893$ ,  $n_2 = 1.446918$ ,  $a = 2.3 \mu\text{m}$  and  $\Delta = 0.75\%$ . Wavelength of zero chromatic dispersion  $C(\lambda_C) = 0$  is  $\lambda_C = 1.523 \mu\text{m}$ , cutoff at  $\lambda_{11G} = 1.073 \mu\text{m}$



# Step-Index Fibre — Dispersion-Compensating and -Flattened

$\lambda / \mu\text{m}$	1.1	1.3	1.56
$V$	2.531	2.141	1.784
$C / \frac{\text{ps}}{\text{km nm}}$	-97.0	-67.0	-50.0

**Table 2.3.** Dispersion characteristics<sup>28</sup> of a step-index DCF with  $n_1 = 1.476754$ ,  $n_2 = 1.446918$ ,  $a = 1.5 \mu\text{m}$  and  $\Delta = 2\%$ , cutoff at  $\lambda_{11G} = 1.158 \mu\text{m}$

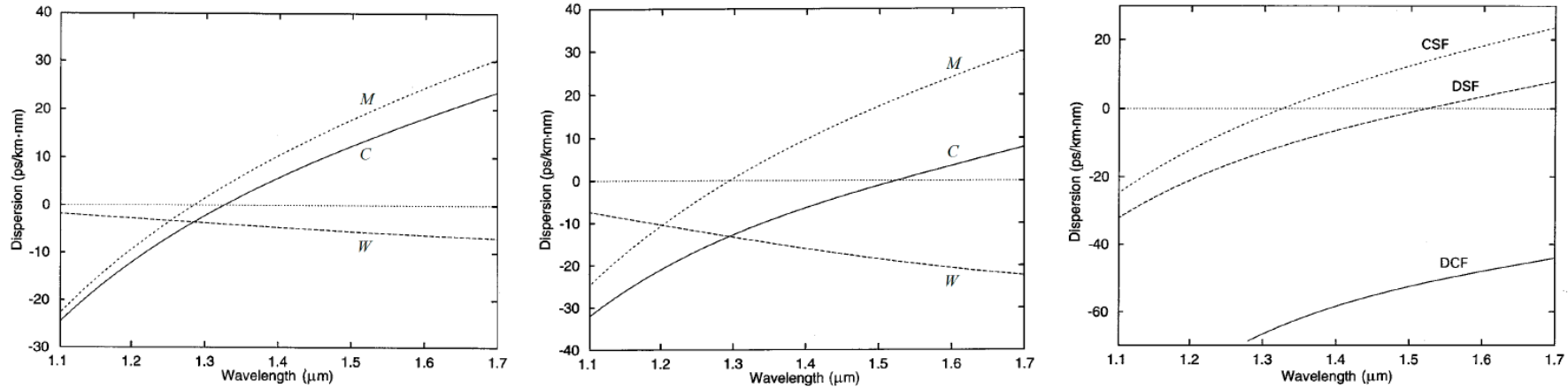


Dispersion characteristics of a triple-clad step-index DFF. (a) Refractive index profile (b) Chromatic dispersion. Quartz glass core with F-doped claddings (computed)  $a_1 = 3.8 \mu\text{m}$ ,  $a_2 = 7 \mu\text{m}$ ,  $a_3 = 12.95 \mu\text{m}$ . Refractive indices at  $\lambda = 1.064 \mu\text{m}$  are  $n_1 = 1.45$ ,  $n_2 = 1.4383$ ,  $n_3 = 1.4471$ ,  $n_4 = 1.4442$ . Three zeros  $C(\lambda_{C1,2,3}) = 0$  at  $\lambda_{C1} = 1.36$ ,  $\lambda_{C2} = 1.48$ ,  $\lambda_{C3} = 1.625 \mu\text{m}$ . (Mantel = cladding)





# Dispersion Characteristics of Step-Index Fibres



(a) CSF:  $\Delta = 0.27\%$ ,  $a = 4.1\ \mu\text{m}$ ,  $\lambda_C = 1.325\ \mu\text{m}$ ,  $\lambda_{11G} = 1.142\ \mu\text{m}$  (Table 2.1)   
 (b) DSF:  $\Delta = 0.75\%$ ,  $a = 2.3\ \mu\text{m}$ ,  $\lambda_C = 1.523\ \mu\text{m}$ ,  $\lambda_{11G} = 1.073\ \mu\text{m}$  (Table 2.2)   
 (c) DCF:  $\Delta = 2\%$ ,  $a = 1.5\ \mu\text{m}$ ,  $\lambda_{11G} = 1.158\ \mu\text{m}$  (Table 2.3). Comparison of CSF, DSF and DCF

**Fig. 2.21.** Dispersion characteristics of basic step-index fibre types with cladding index  $n_2 = 1.446918$  as described in Tables 2.1–2.3. (a), (b) Upper curves: Material dispersion  $M$ . Lower curves: Waveguide dispersion  $W$ . Middle curves: Total chromatic dispersion  $C$  (all in units of ps/(km nm)), see Eq. (2.55) on Page 27. (c) Comparison of CSF (upper curve), DSF (middle curve) and DCF (lower curve) [adapted from Figs. 10.2–10.4 in reference Footnote 25 on Page 39]

$$\Delta t_g/L = C \Delta\lambda + D (\Delta\lambda)^2 + \dots, \quad C = \frac{1}{L} \frac{dt_{gm}}{d\lambda}, \quad D = \frac{1}{2L} \frac{d^2 t_{gm}}{d\lambda^2}$$

$$C(\lambda_C) = 0, \quad \lambda_C \text{ is zero of } C(\lambda_C) \text{ for mode } m.$$

$$\Delta t_g/L = C_\lambda(\lambda) \Delta\lambda = (C + D \Delta\lambda) \Delta\lambda, \quad \text{slope } D = \frac{dC_\lambda(\lambda)}{d\lambda}$$



# Singlemode Impulse Response



Analytic transfer function  $\bar{h}_m(f)$ , causal real impulse response  $h_m(t)$  in mode  $m$ ,  $\beta_m(\omega) = -\beta_m(-\omega)$ :

$$\bar{h}_m(f) = e^{-j\beta_m(\omega)L}, \quad h_m(t) = \int_{-\infty}^{+\infty} \bar{h}_m(f) e^{j2\pi ft} df$$

Distortion-less transmission in vacuum:

$$\beta_m(\omega) = k_0 = \frac{\omega}{c}, \quad h_m(t) = \delta\left(t - \frac{L}{c}\right), \quad u(t) \rightarrow w(t) = u\left(t - \frac{L}{c}\right)$$

Signal spectra concentrated near  $f_0$ ,  $\beta_m^{(i)} = d^i \beta_m(\omega) / d\omega^i |_{\omega=\omega_0}$ :

$$\beta_m(\omega) \approx \beta_m^{(0)} + (\omega - \omega_0)\beta_m^{(1)} + \frac{(\omega - \omega_0)^2}{2!} \beta_m^{(2)} + \frac{(\omega - \omega_0)^3}{3!} \beta_m^{(3)}$$

Phase delay  $L\beta_m^{(0)} / \omega_0 = t_{pm}$  and group delay  $L\beta_m^{(1)} = t_{gm}$ .

Terms up to  $\beta_m^{(1)}$ :  $A_0(t - t_{gm}) e^{j\omega_0(t - t_{pm})}$

Envelope  $A_0(t)$  unchanged, delayed by  $t_g$ , carrier phase retarded by  $\omega_0 t_{pm}$ . — Higher-order terms  $\beta_m^{(i \geq 2)}$ : Linear distortions



## Distortion-free Transmission

Input signal:  $a_0(t) = A_0(t) \exp[j\omega_0 t] \longleftrightarrow \bar{A}_0(f - f_0)$ :

Transfer function:  $\bar{h}_m(f) = e^{-j(\beta_m^{(0)} + (\omega - \omega_0)\beta_m^{(1)})L}$

Signal spectrum at  $z = L$ :  $\bar{A}_0(f - f_0) e^{-j(\beta_m^{(0)} + (\omega - \omega_0)\beta_m^{(1)})L}$

Output signal:

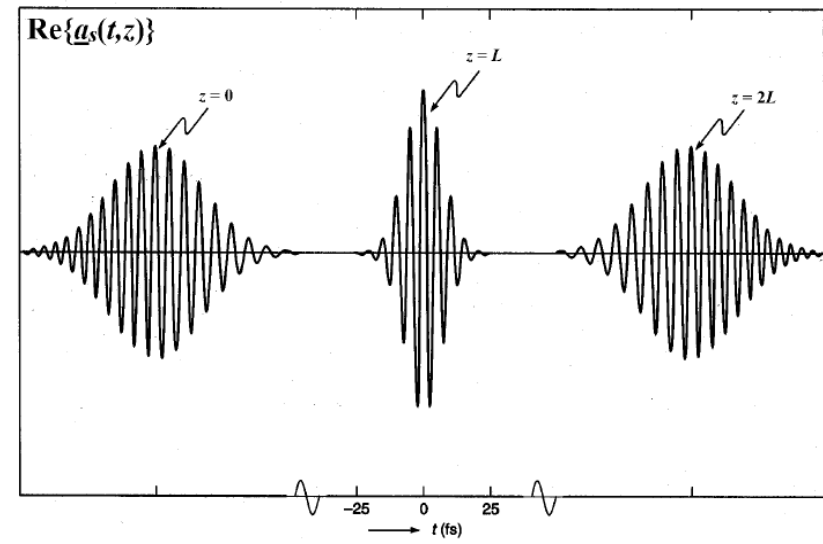
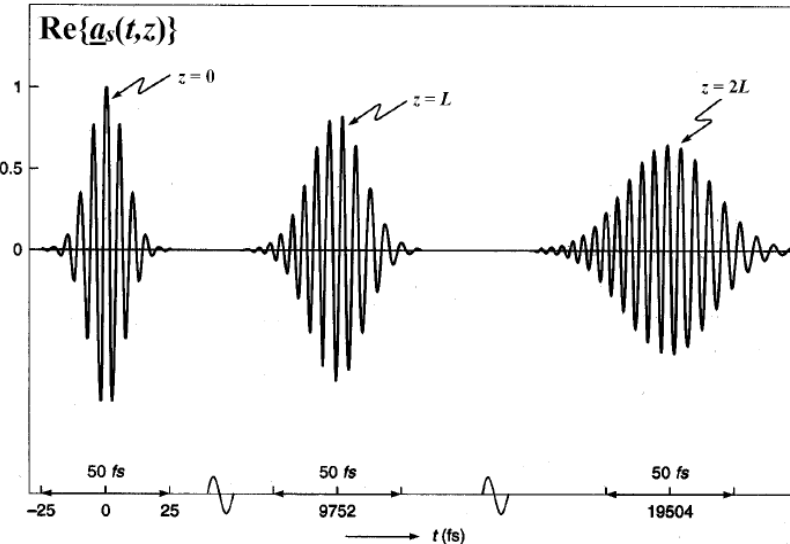
$$\begin{aligned}
 a_L(t) &= \int_{-\infty}^{+\infty} \bar{A}_0(f - f_0) e^{-j(\beta_m^{(0)} + (\omega - \omega_0)\beta_m^{(1)})L} e^{j2\pi ft} df \\
 &= e^{-j(\beta_m^{(0)} - \omega_0\beta_m^{(1)})L} \int_{-\infty}^{+\infty} \bar{A}_0(f - f_0) e^{-j\omega\beta_m^{(1)}L} e^{j2\pi ft} df \\
 &= e^{-j(\beta_m^{(0)} - \omega_0\beta_m^{(1)})L} \int_{-\infty}^{+\infty} \bar{A}_0(f - f_0) e^{j2\pi f(t - \beta_m^{(1)}L)} df \\
 &= e^{-j(\beta_m^{(0)} - \omega_0\beta_m^{(1)})L} \int_{-\infty}^{+\infty} \bar{A}_0(f') e^{j2\pi(f' + f_0)(t - \beta_m^{(1)}L)} df' \\
 &= e^{j\omega_0(t - \frac{\beta_m^{(0)}}{\omega_0}L)} \int_{-\infty}^{+\infty} \bar{A}_0(f') e^{j2\pi f'(t - \beta_m^{(1)}L)} df' \\
 a_L(t) &= A_0(t - \beta_m^{(1)}L) \exp\left[j\omega_0\left(t - \frac{\beta_m^{(0)}}{\omega_0}L\right)\right]
 \end{aligned}$$



# LECTURE 9



# Gaussian Impulse — Visualized



(a) CSF:  $C_{\text{CSF}} = 16 \text{ ps}/(\text{km nm})$  (Table 2.1)

(b) DCF:  $C_{\text{DCF}} = -32 \text{ ps}/(\text{km nm})$  (Table 2.3)



Propagation of a light impulse with a Gaussian envelope. Displayed is the real part  $a_s(t, z) = \Re\{A(t, z) \times \exp[j(\omega_0 t - \beta^{(0)} z)]\}$  of the analytic signal  $\underline{a}_s(t, z)$  for  $\lambda_0 = 1.55 \mu\text{m}$ ,  $z_0 = 0$ ,  $z \geq 0$ , Eq. (2.123) on Page 56. For the chromatic dispersion, see Table 2.1 on Page 47 (CSF), and compare to Table 2.3 on Page 49 (DCF) [adapted from reference Footnote 37 on Page 62].



# Commercial Singlemode Fibre Data

Fiber Type	Attenuation	Chromatic Dispersion		MFD	Polarization
	$\alpha_0$ [dB/km]	$D$ [ps/nm/km]	$D'$ slope [ps/nm <sup>2</sup> /km]	$A_{eff}$ [ $\mu\text{m}^2$ ]	PMD [ps/ $\sqrt{\text{km}}$ ]
PirelliWIDELIGHT_1550	0.24	-6.85	0.157	51	$\leq 0.1$
PirelliWIDELIGHT_1625	0.25	-0.1	0.107	51	$\leq 0.1$
PirelliFREELIGHT_1550	0.23	4.3	0.114	72	$\leq 0.1$
PirelliFREELIGHT_1625	0.25	11.2	0.11	72	$\leq 0.1$
PirelliDEEPLIGHT_1550	0.23@1560nm	-2.2 @1560nm	0.12	70	$\leq 0.1$
CorningSMF28_1310	0.34	0 @1313nm	0.086	66.5	$\leq 0.1$
CorningSMF28_1550	0.19	16	0.086	85	$\leq 0.1$
CorningSMF28e_1310	0.34	0 @1313nm	0.086	66.5	$\leq 0.1$
CorningSMF28e_1550	0.19	16		85	$\leq 0.1$
CorningLEAF	0.2 @1550nm	4 @1550nm	0.1 @1550nm	72	$\leq 0.1$
CorningLEAF_submarine	0.2 @1550nm	0 @1580nm	0.11 @1580nm	71	$\leq 0.1$
FurukawaSMF332_1310	0.32	0	0.092	68	$\leq 0.5$
FurukawaSMF332_1550	0.18	18	0.092	86.5	$\leq 0.5$
AlcatelSMF_1310	0.3	0	0.086	63.6	$\leq 0.1$
AlcatelSMF_1550	0.2	16		81.67	$\leq 0.1$
AlcatelTERALIGHT_1550	0.205	8	0.058	65	$\leq 0.1$
AlcatelTERALIGHT_1620	0.22	10.9 @1600nm	0.058	65	$\leq 0.1$
LucentTRUEWAVE_1600	0.2	4.5	0.045	55	$\leq 0.1$
LucentTRUEWAVE_1550	0.2	7	0.045	59	$\leq 0.1$
LucentALLWAVE_1310	0.3	0 @1312nm	0.088	66	$\leq 0.1$
LucentALLWAVE_1550	0.2	0 @1312nm	0.088	80	$\leq 0.1$
SumitomoZ_1550	0.17	18.5	0.056	80	
SumitomoZPLUSa_1550	0.168	20.5	0.059	110	





# Polarization Mode Dispersion (PMD). Signal Quality (Eye Opening)

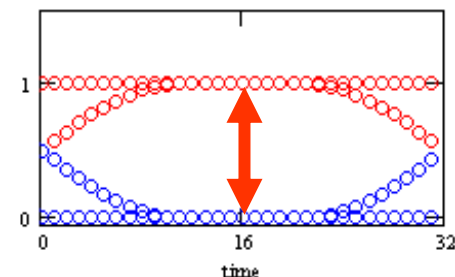
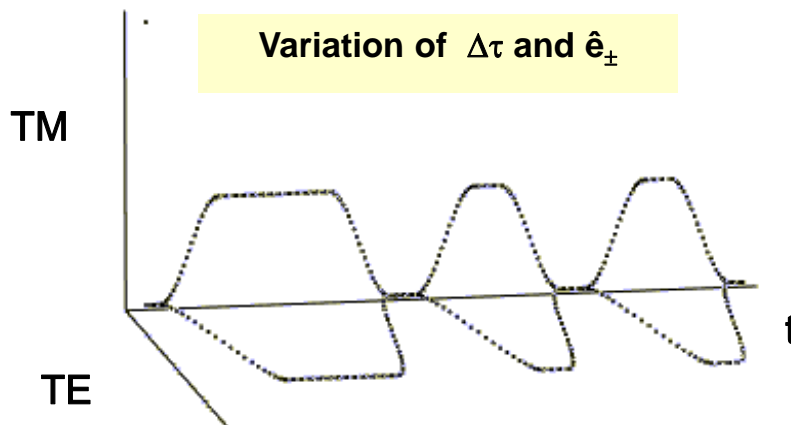
SOP: State-of Polarization

Variation of eye diagram

## First-order PMD

- $d\Delta\tau/d\omega=0$
- $d\hat{e}_{\pm}/d\omega=0$

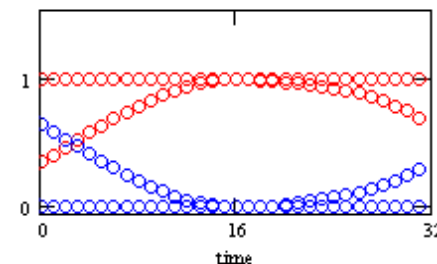
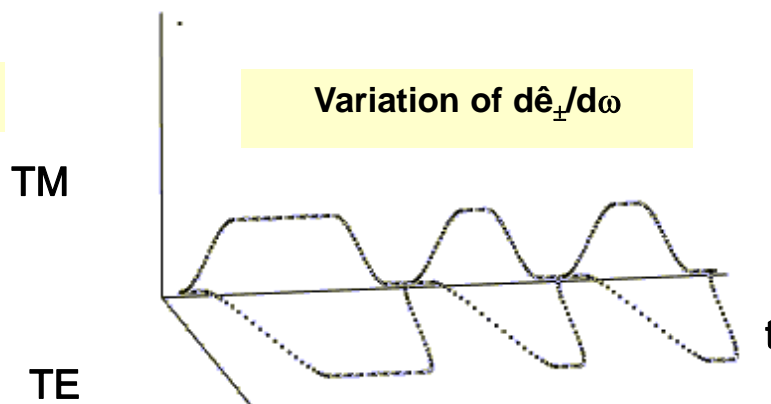
*pulse broadening  
(pulse splitting)*



## Higher-order PMD

- $d\Delta\tau/d\omega \neq 0$
- $d\hat{e}_{\pm}/d\omega \neq 0$

*(overshoots)*

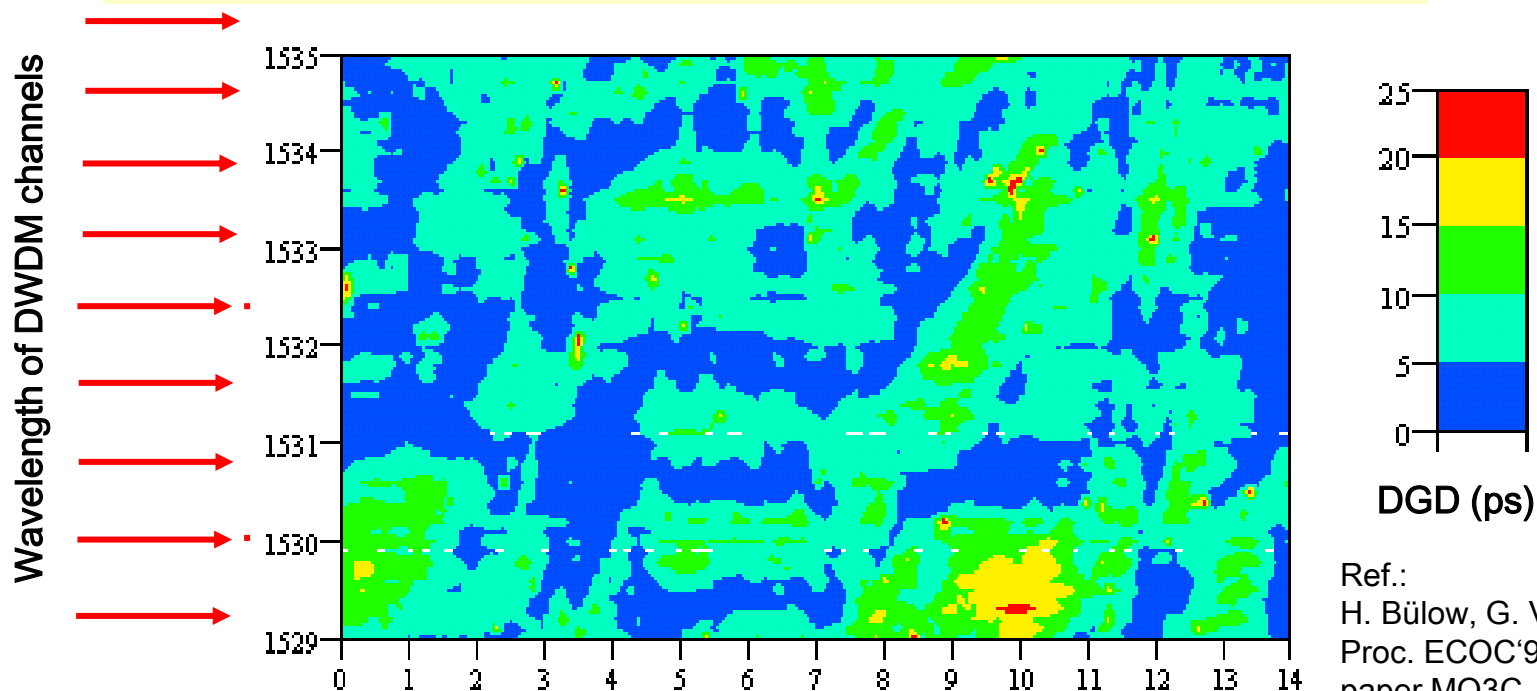


➤ PMD induces stochastic variations of fiber channel transmission paths



# Polarization Mode Dispersion (PMD)

Long term PMD measurement of installed field fibre (246 km G.652 DTAG link Stuttgart/Baden-Baden):  
Statistical PMD variations vs. time and vs. wavelength



➤ Observed statistical PMD variations might have impact on quality of transmission at high bit rates of 10Gbit/s and beyond (40G, 100G)



# Weakly Guiding Fibre — Parabolic-Index Profile ▶

Analytical solution of scalar Helmholtz equation for (unphysically) infinitely extended parabolic refractive index profile:

$$n^2(r) = n_1^2 [1 - 2\Delta g(r/a)]$$

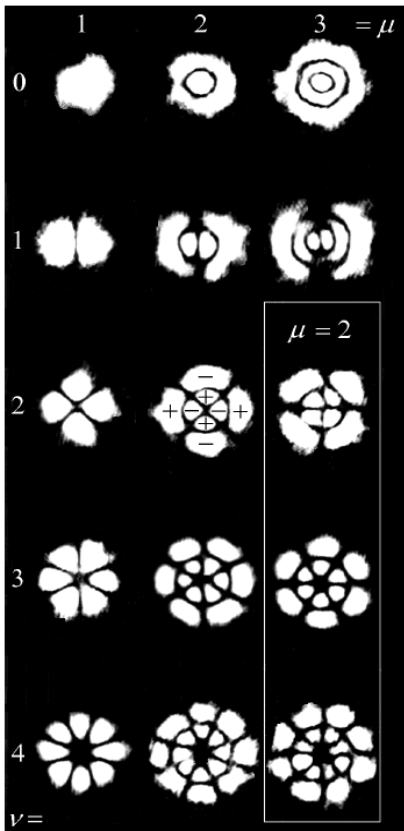
$$g(r/a) = (r/a)^2 \quad \text{in } 0 \leq r < \infty$$

Gauss-Laguerre  $LP_{\nu\mu}$  modes, number:

$$M_g \approx \frac{V^2}{4}, \quad V \gg 1$$

Maximum group delay difference: ▶


$$\frac{\Delta t_g \max}{L} \approx \frac{n_1}{c} \frac{\Delta^2}{2}$$



Gauss-Laguerre modes of a parabolic-index fibre with parameters  $a = 23 \mu\text{m}$ ,  $A_N = 0.2$ ,  $V = 46$  at  $\lambda = 0.6328 \mu\text{m}$ . The beam radius of the fundamental  $LP_{01}$ -mode is  $w_0 = 4.8 \mu\text{m}$ .



# Orthogonality and Coupling Efficiency (1)

Plane  $z = z'$ , scalar light field  $\Phi(r, \varphi, z)$ , total power  $P_\Phi$ . Source field  $\Phi(r, \varphi, z \geq z')$  expanded into set of orthonormal guided modes  $\Psi_{\nu\mu}(r, \varphi, z)$  ( $n_1 \approx n_2 \approx n(r)$ ) and non-guided modes (NG): 

$$\Phi(r, \varphi, z) = \sum_{\nu, \mu} c_{\nu\mu}(z') \Psi_{\nu\mu}(r, \varphi, z) + \text{NG},$$

$$P_\Phi = \frac{n_1}{2} \int_0^{2\pi} \int_0^\infty |\Phi(r, \varphi, z)|^2 r \, dr \, d\varphi$$

$c_{\nu\mu}$  called excitation-, coupling-, Fourier coefficients.

By multiplying with  $\Psi_{\nu'\mu'}^*(r, \varphi, z')$  at  $z = z'$  and integrating over cross-sectional area (disregarding for now NG):

$$\begin{aligned} & \int_0^{2\pi} \int_0^\infty \Phi(r, \varphi, z') \Psi_{\nu'\mu'}^*(r, \varphi, z') r \, dr \, d\varphi \\ &= \sum_{\nu, \mu} c_{\nu\mu}(z') \underbrace{\int_0^{2\pi} \int_0^\infty \Psi_{\nu\mu}(r, \varphi, z') \Psi_{\nu'\mu'}^*(r, \varphi, z') r \, dr \, d\varphi}_{\delta_{\nu\nu'} \delta_{\mu\mu'} / n_1} \end{aligned}$$



## Orthogonality and Coupling Efficiency (2)

Orthogonality of guided ◀ and non-guided modes ◀ (not proven here), sum reduces to one element:

$$\sum_{\nu, \mu} c_{\nu\mu}(z') \delta_{\nu\nu'} \delta_{\mu\mu'} / n_1 = c_{\nu'\mu'}(z') / n_1, \quad P = \frac{1}{2} \sum_{\nu, \mu} |c_{\nu\mu}(z')|^2,$$

$$c_{\nu\mu}(z') = n_1 \int_0^{2\pi} \int_0^{\infty} \Phi(r, \varphi, z') \Psi_{\nu\mu}^*(r, \varphi, z') r \, dr \, d\varphi$$

Sum of modal powers  $|c_{\nu\mu}|^2/2$  equals total guided power  $P$ :

$$P = \frac{1}{2} \sum_{\nu, \mu} \sum_{\nu', \mu'} c_{\nu\mu}(z') c_{\nu'\mu'}^*(z') n_1 \underbrace{\int_0^{2\pi} \int_0^{\infty} \Psi_{\nu\mu}(r, \varphi, z) \Psi_{\nu'\mu'}^*(r, \varphi, z) r \, dr \, d\varphi}_{\delta_{\nu\nu'} \delta_{\mu\mu'}}$$



## Orthogonality and Coupling Efficiency (3)

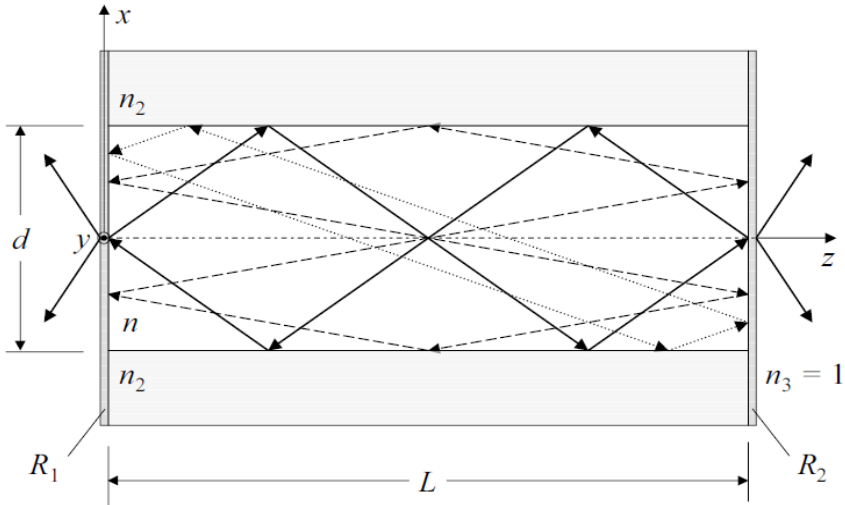
Generally complex field  $\Phi(r, \varphi, z = 0) \equiv \Phi(r, \varphi)$  launched at fibre entrance  $z' = 0$ . Fraction  $\eta_{\nu\mu}$  of total power  $P_\Phi$  coupled to guided modes  $\Psi_{\nu\mu}(r, \varphi, z = 0) \equiv \Psi_{\nu\mu}(r, \varphi)$  ( $c_{\nu\mu} \equiv c_{\nu\mu}(z' = 0)$ ):

$$\eta_{\nu\mu} = \frac{|c_{\nu\mu}|^2}{2P_\Phi} = \frac{\left| \int_0^{2\pi} \int_0^\infty \Phi(r, \varphi) \Psi_{\nu\mu}(r, \varphi) r \, dr \, d\varphi \right|^2}{\int_0^{2\pi} \int_0^\infty |\Phi(r, \varphi)|^2 r \, dr \, d\varphi \int_0^{2\pi} \int_0^\infty \Psi_{\nu\mu}^2(r, \varphi) r \, dr \, d\varphi}$$





# Semiconductor Laser — Counting Resonator Modes



- 1D WG: transv.  $x$ -resonances
- 2D WG: transv.  $(x, y)$ -resonances
- 3D resonator has in addition longitudinal  $z$ -resonances.



Vol.  $V = Lbd$ , or configuration-space volume  $V_c = L_x L_y L_z \hat{=} L^3$

**Fig. 3.1.** Laser resonator modes. Resonator length  $L$ , strip waveguide height  $d$  (corresponds to  $h$  in Fig. 2.7), strip waveguide height  $b$  along  $y$ -axis, active volume  $V = Lbd$ , mirrors with power reflection factors  $R_{1,2}$

1D :  $M_g^{(\text{slab})} = \frac{4}{\pi} V = 2 \left( 2 \frac{h}{2} \right) \frac{f}{c} (2 A_N) \quad (V = \frac{h}{2} k_0 A_N)$

2D :  $M_g^{(\text{SIF})} = \frac{1}{2} V^2 = 2 (a^2 \pi) \frac{f^2}{c^2} (\pi A_N^2) \quad (V = a k_0 A_N)$

3D :  $M_{\text{tot}} = 2 V_c \frac{4\pi}{3} \left( \frac{fn}{c} \right)^3 = \frac{2}{3} (L^3) \frac{f^3}{c^3} (4\pi), \quad n = 1$

DOS :  $\varrho_{\text{tot}}(f) = \frac{1}{V_c} \frac{dM_{\text{tot}}}{df} = \frac{8\pi}{c^3} (fn)^2 n_g, \quad n_g = n + f \frac{dn}{df}$

# Free Electron as a Wave Function

Electron moving in constant potential  $V$  having momentum  $p$ .

De Broglie: Described by plane-wave function, angular frequency

$\omega$ , wavenumber  $k = p/\hbar$  (physics notation; electrical engineering:

$\psi_{ee}(t, x) = \exp[j(\omega t - kx)] = \psi^*(x, t)$ ):

$$\psi(x, t) = \exp[j(kx - \omega t)]$$

Electron may be excited only with energy quanta  $\hbar\omega = W$  (Einstein, photoelectric effect). Result is matter wave:

$$\psi(x, t) = \exp[(j/\hbar)(px - Wt)]$$

Derivatives of  $\psi(x, t)$  wrt  $x$  and  $t \rightarrow$  differential operators for conservation quantities. Eigenvalues are momentum  $p$  and energy  $W$ :

$$(-j\hbar\partial/\partial x)^2\psi(x, t) = p^2\psi(x, t), \quad j\hbar(\partial/\partial t)\psi(x, t) = W\psi(x, t)$$

Electron energy  $W = p^2/(2m_0) + V = (\hbar k)^2/(2m_0) + V$ , rest mass  $m_0$ :

$$\left[ \frac{1}{2m_0} \left( \frac{\hbar\partial}{j\partial x} \right)^2 + V \right] \psi(x, t) = -\frac{\hbar\partial}{j\partial t} \psi(x, t)$$



# Schrödinger Equation for “Bound Electron” & “Two-Level Atom”

**Wave function**  $\psi(x, t) = \psi(x) e^{-j\omega t}$  and dispersion relation:

$$\left[ \frac{1}{2m_0} \left( \frac{\hbar}{j} \frac{\partial}{\partial x} \right)^2 + V \right] \psi(x) = W \psi(x), \quad W = \hbar\omega = \frac{(\hbar k)^2}{2m_0} + V$$

**Potential film** ( $\hat{=}$  slab waveguide) with infinitely high walls. Solutions are spatial sinusoidals or superpositions of it:

$$\psi(x, t) = j(1/\sqrt{2}) \psi_2(x) e^{-j\omega_2 t} + (1/\sqrt{2}) \psi_1(x) e^{-j\omega_1 t},$$
$$\omega_{21} = \omega_2 - \omega_1$$

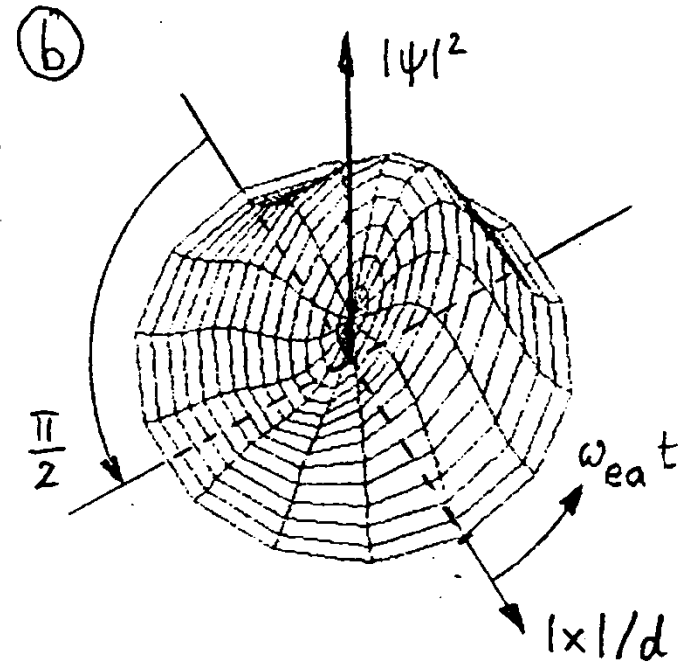
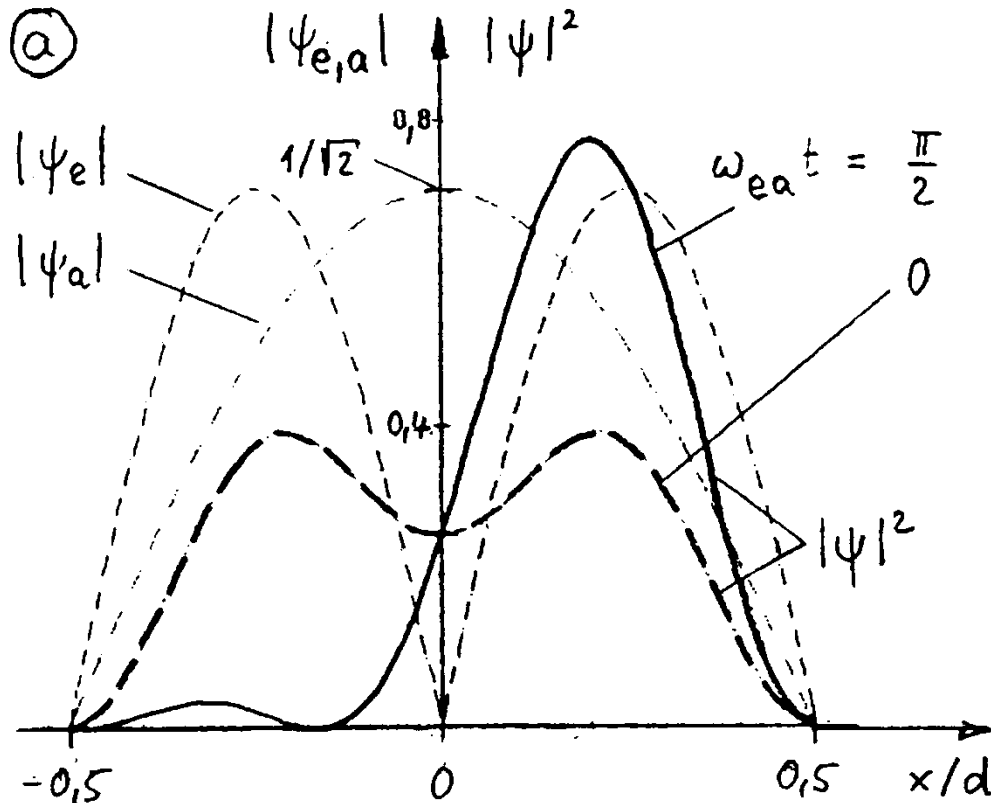


# Schrödinger Equation for "Two-Level Atom"

Potential film ( $\hat{=}$  slab waveguide) with infinitely high walls. Solutions are spatial sinusoidals or superpositions of it:

$$\psi(x, t) = j(1/\sqrt{2}) \psi_2(x) e^{-j\omega_2 t} + (1/\sqrt{2}) \psi_1(x) e^{-j\omega_1 t},$$

$$\omega_{21} = \omega_2 - \omega_1$$



# Schrödinger Equation for “Bound Electron” & “Two-Level Atom”

**Wave function**  $\psi(x, t) = \psi(x) e^{-j\omega t}$  and dispersion relation:

$$\left[ \frac{1}{2m_0} \left( \frac{\hbar}{j} \frac{\partial}{\partial x} \right)^2 + V \right] \psi(x) = W \psi(x), \quad W = \hbar\omega = \frac{(\hbar k)^2}{2m_0} + V$$

**Potential film** ( $\hat{=}$  slab waveguide) with infinitely high walls. Solutions are spatial sinusoidals or superpositions of it:

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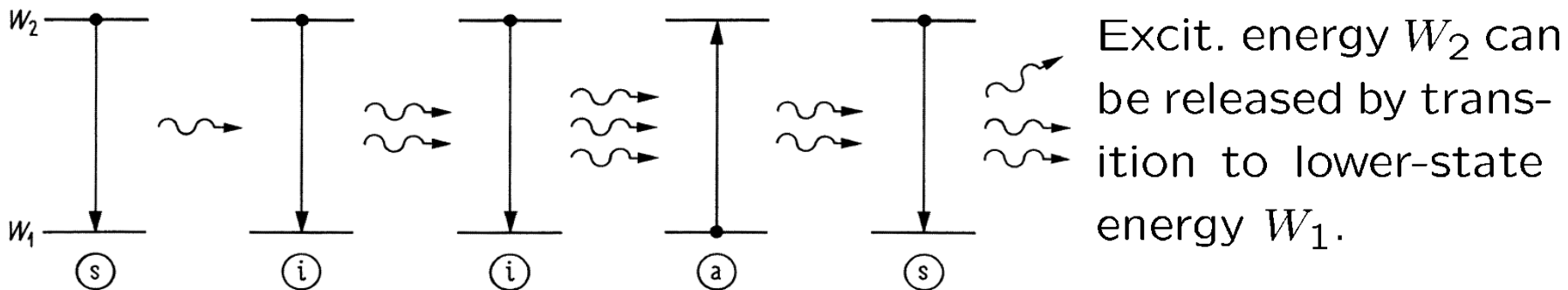
**Light-matter interaction** of wave function  $\psi(x, t)$  with electric field  $E_0(t)$ . Dipole moment  $\mu = -ex$  leads to dipole energy  $-\mu E_0(t)$ :

$$\left[ \frac{1}{2m_0} \left( \frac{\hbar}{j} \frac{\partial}{\partial x} \right)^2 + V(x) + ex E_0(t) \right] \psi(x, t) = -\frac{\hbar}{j} \frac{\partial}{\partial t} \psi(x, t)$$

**Dipole approximation**  $\rightarrow$   $t$ -dependent coefficients  $c_{1,2}(t)\psi_{1,2}(x) \rightarrow$   
 $E_0$ -field with  $\omega_0 = \omega_{21} \rightarrow$  envelope with **Rabi frequ.**  $\omega_{\mathcal{R}} = \frac{|\mu_{21}| \hat{E}_0}{\hbar}$ .



# Luminescence and Laser Radiation



**Radiative transition**, emitting or absorbing photon  $hf = W_2 - W_1$ .

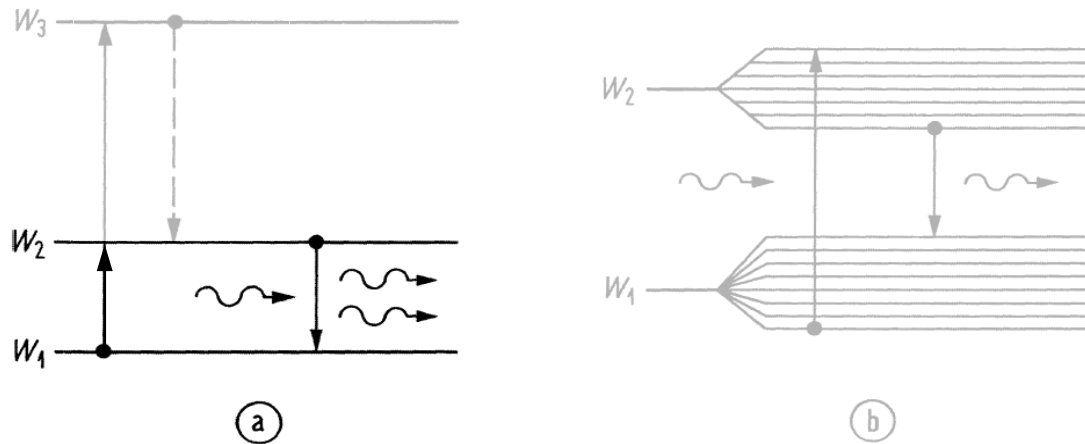
**Fig. 3.2.** Interaction of a two-level microsystem with electromagnetic radiation, photon energy  $hf = W_2 - W_1$ . (a) absorption, (s) spontaneous emission, and (i) induced (= stimulated) emission of photons

- **Absorption** Microsystem in ground state  $W_1$  absorbs radiation at a frequency  $f = (W_2 - W_1)/h \rightarrow$  upward transition to  $W_2 \rightarrow$  induced or stimulated by an existing field.
- **Spontaneous emission** Excited microsystem in  $W_2$  makes transition to ground state  $W_1$  “spontaneously” by emitting a photon with energy  $hf = W_2 - W_1$  after an average lifetime  $\tau_{sp}$ .
- **Induced emission**  $W_2 \rightarrow W_1$  induced or stimulated by radiation at  $f = (W_2 - W_1)/h$ . In contrast to SE: Phase coherence, same mode as stimulating radiation  $\rightarrow$  amplification.





# Laser Active Materials — Two-Level Systems (2)



**Fig. 3.3.** Pump mechanism using energy levels (a) outside (three-level laser system) or (b) inside the energy level group of the laser transition (pseudo-four-level laser system)

SE reduces  $N_2 \sim t$ , induced emission reduces  $N_2 \sim N_P t$ . With elmag field of photon energy  $hf \rightarrow$  dynamic equilibrium:

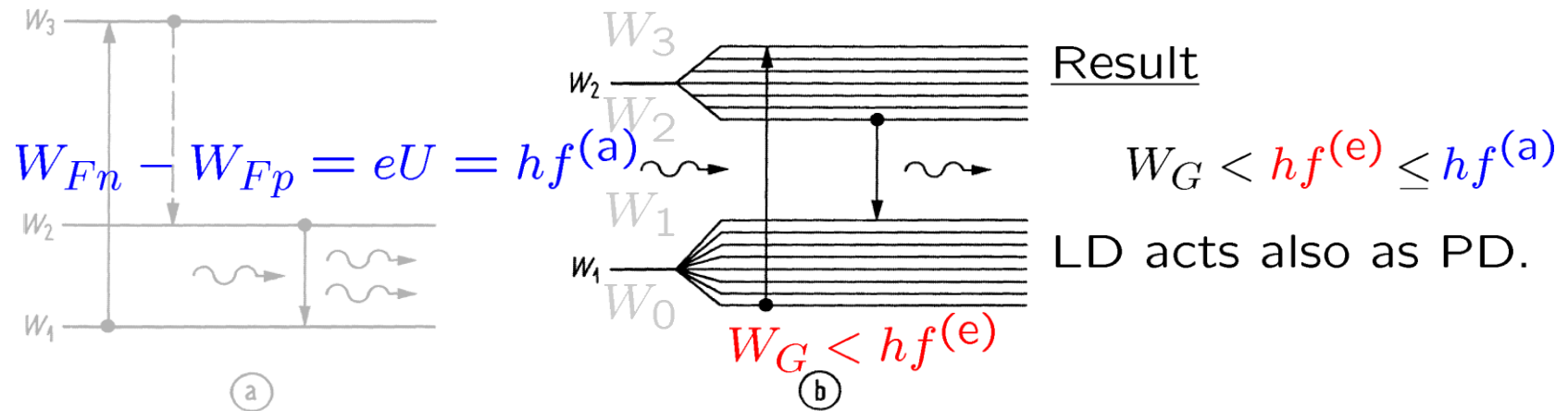
$$(\text{induced emissions}) = (\text{induced absorptions})$$

For large  $N_P$ , SE is negligible  $\rightarrow$  dynamic equilibrium  $N_2 = N_1$  (with SE:  $N_2 \leq N_1$ ). Medium is “transparent” in this case.

With two-level system no population inversion, no gain!



# Laser Active Materials — Semiconductors

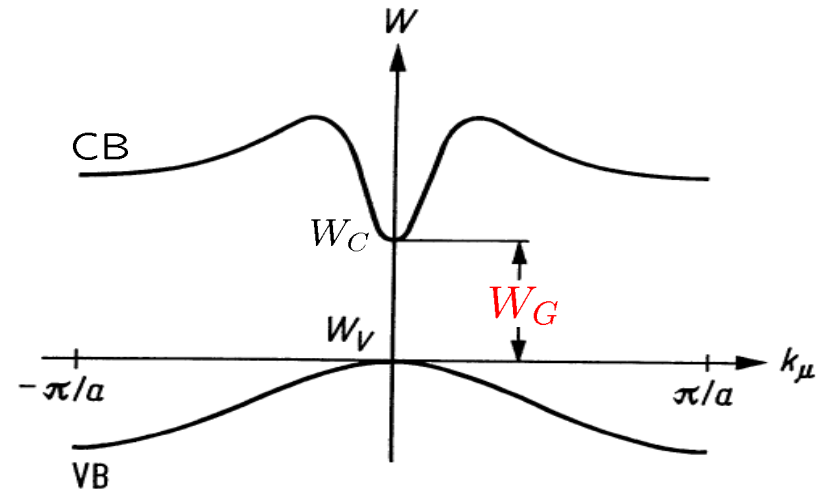
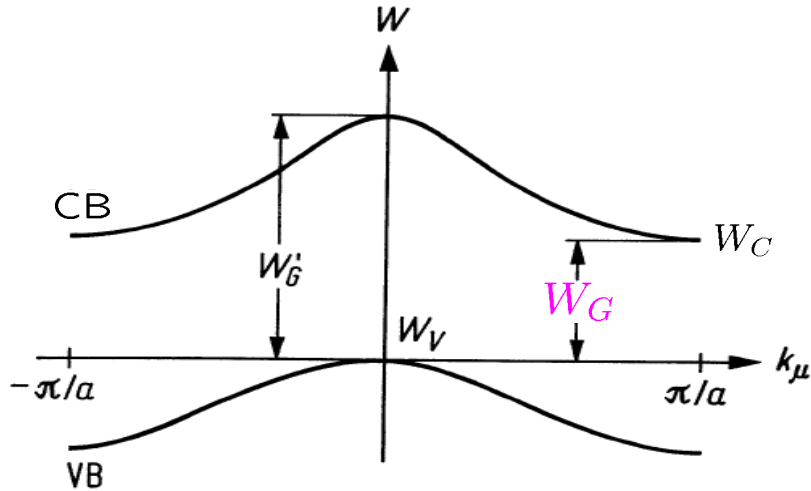


**Fig. 3.3.** Pump mechanism using energy levels (a) outside (three-level laser system) or (b) inside the energy level group of the laser transition (pseudo-four-level laser system)

Levels  $W_2$  and  $W_1$  associated with conduction and valence band states. Absorbed pump  $hf^{(a)}$  ( $\cong W_3 - W_0$ ) generates electron-hole pairs. Also with forward biased pn-diode by injecting electrons and holes for a population inversion. At  $T = 0$ , forward voltage  $U$  defines “pump energy”  $eU = hf^{(a)} =$  (energetic difference at which electrons and holes are injected) = (difference of the quasi Fermi levels).



# Band Structure of Direct and Indirect Semiconductors



Indirect semicond. Smallest transition energy  $W_G$  for crystal momentum diff.  $\Delta k_\mu = \pi/a$ . Phonon required as collision partner  $\rightarrow$  Radiative transition unlikely. Examples: Elemental semiconductors Si, Ge

$$W_G = \begin{cases} 0.67 \text{ eV} \cong 1.85 \mu\text{m} & (\text{Ge}) \\ 1.13 \text{ eV} \cong 1.10 \mu\text{m} & (\text{Si}) \end{cases}$$

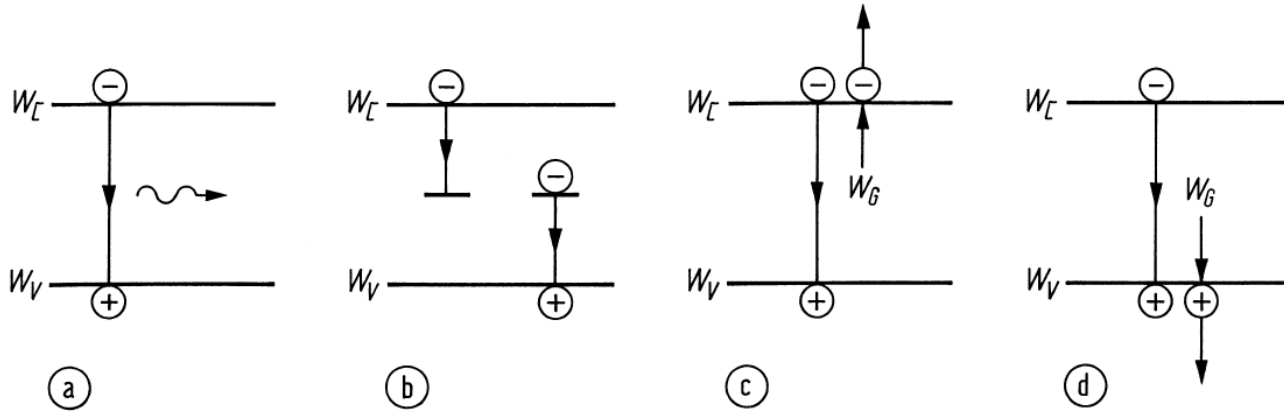
$$W'_G = \begin{cases} 0.8 \text{ eV} \cong 1.55 \mu\text{m} & (\text{Ge}) \\ 3.4 \text{ eV} \cong 0.36 \mu\text{m} & (\text{Si}) \end{cases}$$

Direct semicond. Smallest transition energy  $W_G$  for crystal momentum difference  $\Delta k_\mu = 0$ . No collision partner required  $\rightarrow$  Radiative transition likely. Examples: Compounds GaAs, InP, InGaAs

$$W_G = \begin{cases} 1.42 \text{ eV} \cong 0.87 \mu\text{m} & (\text{GaAs}) \\ 1.80 \text{ eV} \cong 0.69 \mu\text{m} & (\text{Ga}_{0.7}\text{Al}_{0.3}\text{As}) \\ 0.75 \text{ eV} \cong 1.65 \mu\text{m} & (\text{In}_{0.53}\text{Ga}_{0.47}\text{As}) \\ 1.35 \text{ eV} \cong 0.92 \mu\text{m} & (\text{InP}) \end{cases}$$



# Radiative and Nonradiative Recombination



**p-Si rad. lifetime**

$$p_p = 10^{16} \text{ cm}^{-3}:$$

$$\tau_{nsp}^{-1} = \frac{\partial r_{sp}}{\partial n_T}$$

$$\tau_{nsp} = 33 \text{ ms}$$

Radiative and nonradiative transitions. (a) Radiative band-band transition. (b) Nonradiative transition via localized states in the forbidden band. (c) (d) Nonradiative Auger recombinations (recombination energy excites an electron in the CB or in the VB)

**Radiative recomb.** (rate  $r_{sp}$ , unit  $\text{cm}^{-3} \text{ s}^{-1}$ ) of electrons and holes:

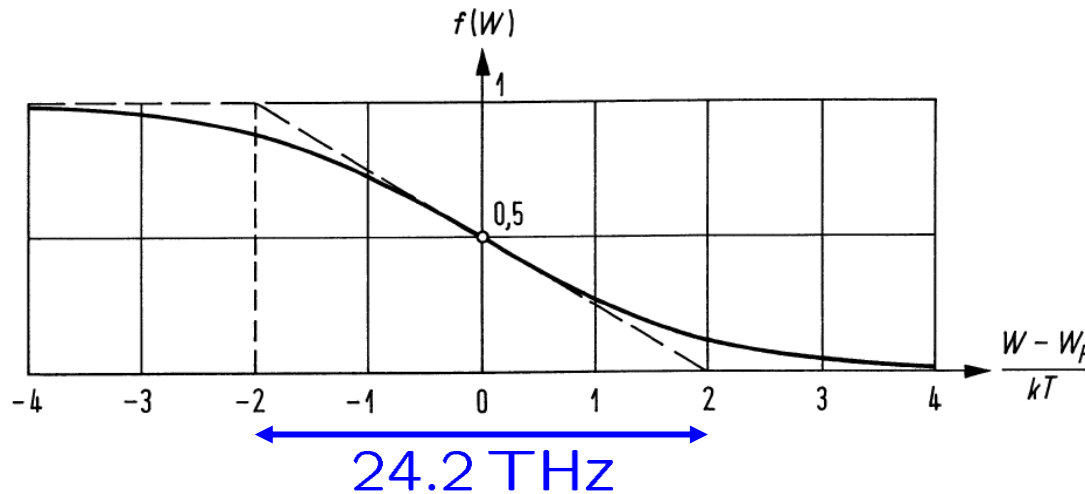
$$r_{sp} = B n_T p, B = \begin{cases} 1 \times 10^{-10} \dots 7 \times 10^{-10} \text{ cm}^3 \text{ s}^{-1} & \text{(Ga,Al)As} \\ 8.6 \times 10^{-11} \text{ cm}^3 \text{ s}^{-1} & \text{(In,Ga)(As,P)} \\ 3 \times 10^{-15} \text{ cm}^3 \text{ s}^{-1} & \text{Si (indirect SC)} \end{cases}$$

**Nonrad. recomb.** (rate  $r_{ns}$ , unit  $\text{cm}^{-3} \text{ s}^{-1}$ ): Localized impurities, rate  $r_{\ell S}$  (Shockley-Read-Hall, SRH). Recomb. energy transferred to  $e$  or  $h$ , rate  $r_{Au}$ , (Auger, in (In,Ga)(As,P)  $\rightarrow h$ , not in (Ga,Al)As):

$$r_{ns} = r_{\ell S} + r_{Au}, \quad r_{\ell S} = A n_T, \quad r_{Au} = C n_T p^2$$



# Filling of Electronic States — Fermi Function



At  $T = 0$  electrons fill lowest energy states. At  $T > 0$  Fermi-Dirac distrib. (Fermi function):

$$f(W) = \frac{1}{1 + g \exp\left(\frac{W - W_F}{kT}\right)}$$

Fig. 3.8. Fermi function for band energy states ( $g = 1$ )

$W_F$  is Fermi energy where occup. prob.  $f(W) = 1/2$  at all  $T$ . Transit. “large  $\rightarrow$  low”: Occup. prob. ( $0.88 \geq f(W) \geq 0.12$ ) in region  $4kT$  centred at  $W_F$  (at  $T = 293$  K:  $kT = 25$  meV or  $\Delta f = 2kT/h = 12.1$  THz). Boltzmann approximation:

$$f(W) \approx g \exp\left(-\frac{W - W_F}{kT}\right) \quad \text{for } W - W_F > 3kT,$$

$$f(W) \approx 1 - g \exp\left(\frac{W - W_F}{kT}\right) \quad \text{for } W - W_F < -3kT.$$



# Impurities, Doping and Carrier Concentration — Equilibrium ▶

Density of states (parabolic bands  $W_{C,V} \sim (\hbar k_\mu)^2 / (2m_{n,p})$ ):

$$\rho_{\frac{C}{V}}(W) = \frac{1}{2\pi^2} \left( \frac{2|m_n|}{\hbar^2} \right)^{3/2} \sqrt{\pm(W - W_{\frac{C}{V}})}, \quad N_{\frac{C}{V}} = 2 \left( \frac{2\pi|m_n|kT}{\hbar^2} \right)^{3/2}$$

Carrier concentrations in CB ( $n_T$ ) and VB ( $p$ ): ◀

$$n_T = \int_{W_C}^{\infty} \rho_C(W) f(W) dW, \quad p = \int_{-\infty}^{W_V} \rho_V(W) [1 - f(W)] dW$$

Boltzmann approximation (valid for  $n_T \ll N_C$ ,  $p \ll N_V$  only, i. e., nondegenerate doping; **not true for semiconductor lasers!**):

$$\left. \begin{aligned} n_T &= N_C \exp\left(-\frac{W_C - W_F}{kT}\right) \\ p &= N_V \exp\left(-\frac{W_F - W_V}{kT}\right) \end{aligned} \right\} n_T p = n_i^2 = N_C N_V \exp\left(-\frac{W_G}{kT}\right)$$

Intrinsic carrier concentration  $n_i$  denotes electrons  $n_T$  (holes  $p$ ) which are present pairwise in CB (VB) of pure undoped semiconductors at temperature  $T$ , independent of Fermi energy  $W_F$ .





# Impurities, Doping and Carrier Concentration — Non-Equilibrium

Density of states (parabolic bands  $W_{C,V} \sim (\hbar k_\mu)^2 / (2m_{n,p})$ ):

$$\rho_{\frac{C}{V}}(W) = \frac{1}{2\pi^2} \left( \frac{2|m_n|}{\hbar^2} \right)^{3/2} \sqrt{\pm(W - W_{\frac{C}{V}})}, \quad N_{\frac{C}{V}} = 2 \left( \frac{2\pi|m_n|kT}{\hbar^2} \right)^{3/2}$$

Carrier concentrations in CB ( $n_T$ ) and VB ( $p$ ):

$$n_T = \int_{W_C}^{\infty} \rho_C(W) f(W) dW, \quad p = \int_{-\infty}^{W_V} \rho_V(W) [1 - f(W)] dW$$

Boltzmann approximation (valid for  $n_T \ll N_C$ ,  $p \ll N_V$  only, i. e., nondegenerate doping), quasi Fermi levels  $W_{Fn,p}$ :

$$\left. \begin{aligned} n_T &= N_C \exp\left(-\frac{W_C - W_{Fn}}{kT}\right) \\ p &= N_V \exp\left(-\frac{W_{Fp} - W_V}{kT}\right) \end{aligned} \right\} \begin{aligned} n_T p &= n_i^2 \exp\left(\frac{W_{Fn} - W_{Fp}}{kT}\right) \\ n_i^2 &= N_C N_V \exp\left(-\frac{W_G}{kT}\right) \end{aligned}$$

Intrinsic carrier concentration  $n_i$  denotes electrons  $n_T$  (holes  $p$ ) which are present pairwise in CB (VB) of pure undoped semiconductors at temperature  $T$ , independent of Fermi energy  $W_F$ .



# Quasi Fermi Levels in Non-Equilibrium

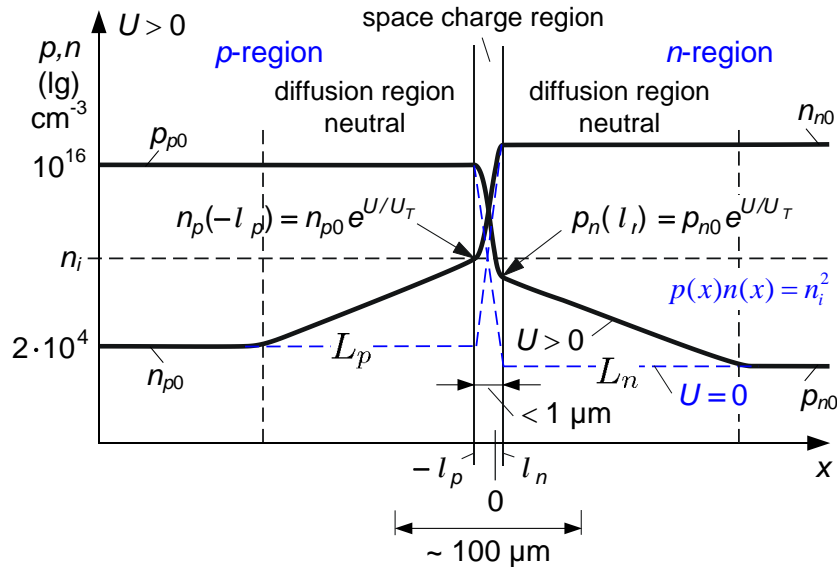
For laser threshold current  $\rightarrow$  carrier concentrations  $n_T, p$  for shifting quasi Fermi levels  $W_{Fn}, W_{Fp}$  into bands. **p-doped semiconductor** with equilibrium concentration of  $n_{T0}, p_0$  and  $n_{T0}p_0 = n_i^2$ . Carrier injection changes densities to  $n_T = n_{T0} + \Delta n_T, p = p_0 + \Delta p$ . Substitution into Fermi function:

$$W_{Fn} - W_F = kT \ln \left( 1 + \frac{\Delta n_T}{n_{T0}} \right), \quad W_F - W_{Fp} = kT \ln \left( 1 + \frac{\Delta p}{p_0} \right)$$

Charge neutrality  $\Delta p = \Delta n_T$ . Carrier injection  $\rightarrow$  quasi Fermi level of minority carriers shifts first (here:  $W_{Fn}$ ; change of  $n_T$  by  $\Delta n_T$  has largest effect because  $n_{T0}$  is small). At  $\Delta n_T/n_{T0} = 1$  shift amounts to  $W_{Fn} - W_F = 0.7 kT$ . Because  $p_0 \gg n_{T0}$  in a p-semiconductor, quasi Fermi level for majority carriers starts shifting at much higher injection current levels when  $\Delta p = \Delta n_T$  reaches the order of  $p_0$ .



# Abrupt pn-Homojunction in Equilibrium (Zero Bias)



Equilibrium  $U = 0$ , zero current:  
 $p$  and  $n$ -type SC joined, majority electrons (holes) diffuse in  $p$  ( $n$ ) region leaving positive (negative) donors (acceptors) in the *space charge region*  $\rightarrow$  **built-in potential** (German: „Diffusionsspannung“):

$$U_D = U_T \ln \frac{n_D n_A}{n_i^2}, \quad U_T = \frac{kT}{e}$$

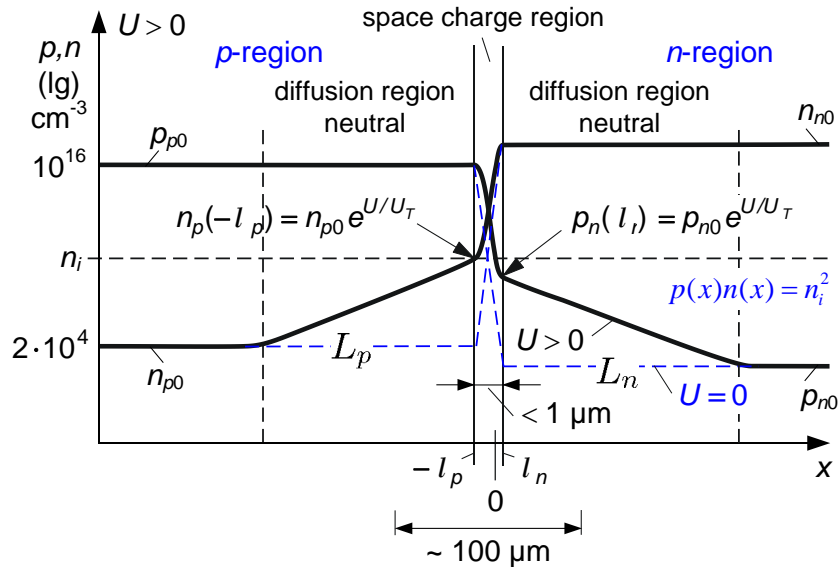
**Built-in electric field** draws minorities across the junction until the minority drift current compensates the majority diffusion current. For each  $x$  the mass action law holds:

(Electron concentration  $n_T \hat{=} n$ )

$$p(x) n_T(x) = n_i^2$$



# Abrupt pn-Homojunction in Equilibrium (Zero Bias)



Equilibrium  $U = 0$ , zero current:  
 $p$  and  $n$ -type SC joined, majority electrons (holes) diffuse in  $p$  ( $n$ ) region leaving positive (negative) donors (acceptors) in the *space charge region*  $\rightarrow$  **built-in potential** (German: „Diffusionsspannung“):

$$U_D = U_T \ln \frac{n_D n_A}{n_i^2}, \quad U_T = \frac{kT}{e}$$

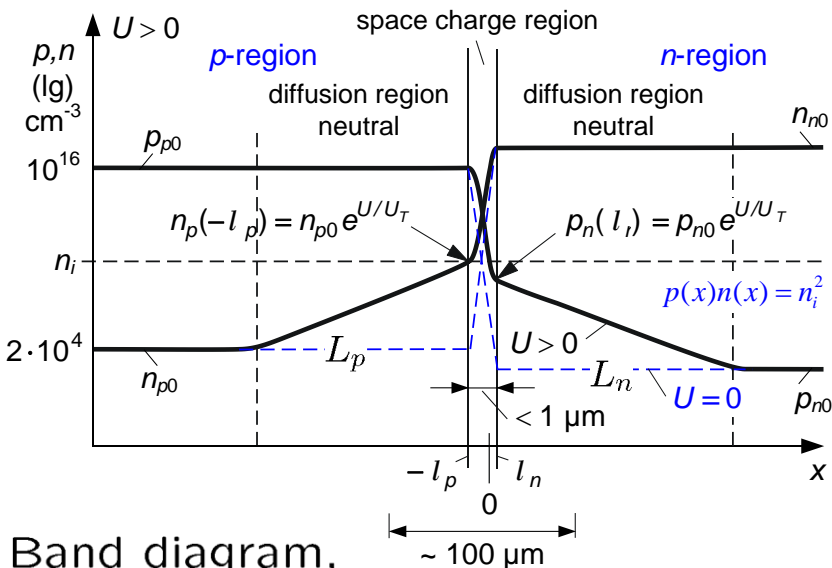
**Built-in potential** such that equilibrium Fermi energy is constant throughout junction:

$$eU(x) = W_{F_n}(x) - W_{F_p}(x) = 0$$

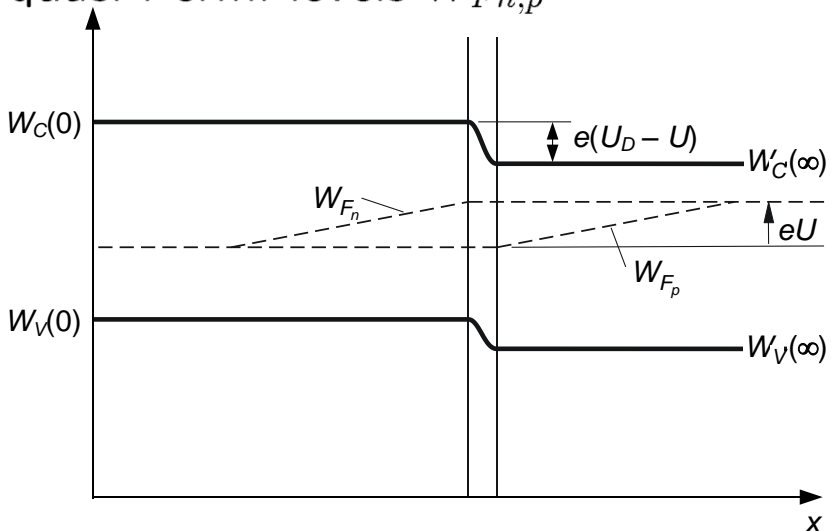
(Electron concentration  $n_T \hat{=} n$ ) **Equilibrium** between carriers of conduction and valance band.



# Abrupt pn-Homojunction in **Non-Equilibrium** (Non-Zero Bias)



Band diagram, quasi Fermi levels  $W_{Fn,p}$



**Non-equilibrium**  $U > 0$ , **forward current**: Built-in potential reduced by bias  $U$  to  $U_D - U$ :

$$eU(x) = W_{Fn}(x) - W_{Fp}(x)$$

**Increased crossing probab.** for majorities  $\rightarrow$  diff. current  $\gg$  saturated minority current  $i_s$ , ext. current  $I$ :

$$I = i_s \exp\left(\frac{U}{U_T}\right) - i_s$$

**Non-equilibrium**  $U \ll U_T$ , **reverse current**: Built-in potential increased  $\rightarrow$  diffusion current negligible wrt minority current  $i_s$ :

$$I = i_s \exp\left(\frac{-|U|}{U_T}\right) - i_s \approx -i_s$$



# Abrupt pn-Homojunction in **Non-Equilibrium** (Non-Zero Bias)

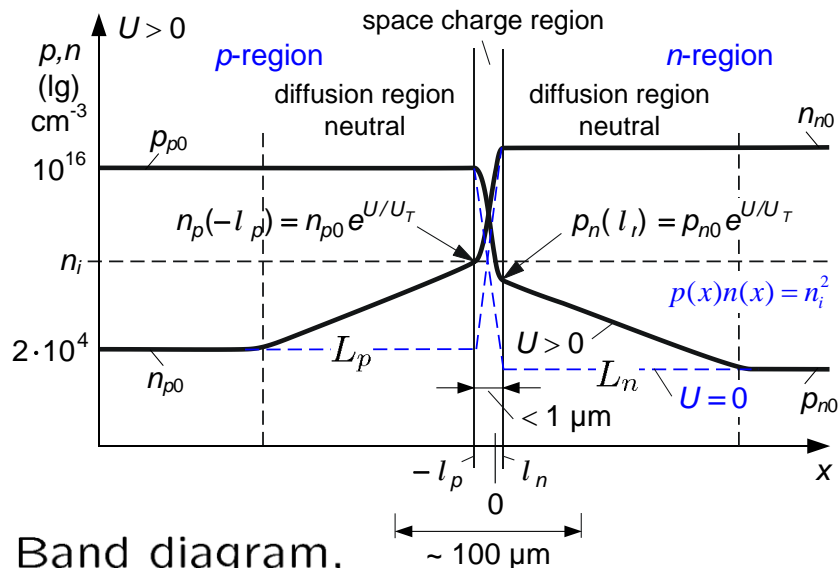
**Non-equilibrium**  $U > 0$ , **forward current**: Built-in potential reduced by bias  $U$  to  $U_D - U$ :

$$eU(x) = W_{F_n}(x) - W_{F_p}(x)$$

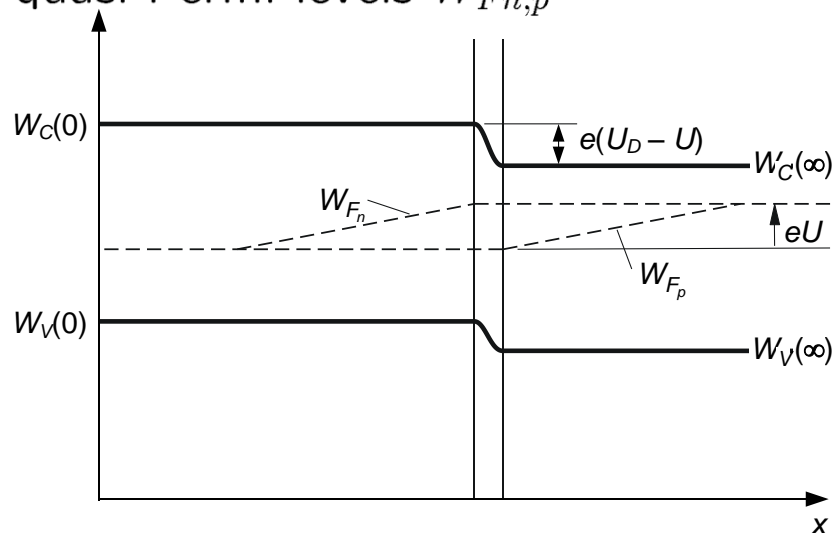
**Increased crossing probab.** for majorities  $\rightarrow$  diff. current  $\gg$  saturated minority current  $i_s$ , ext. current  $I$ :

$$I = i_s \exp\left(\frac{U}{U_T}\right) - i_s$$

**Quasi Fermi levels**  $W_{F_n,p}$  result. Carriers inside respective bands still in equilibrium, but no equilibrium between carriers of conduction and valence bands.

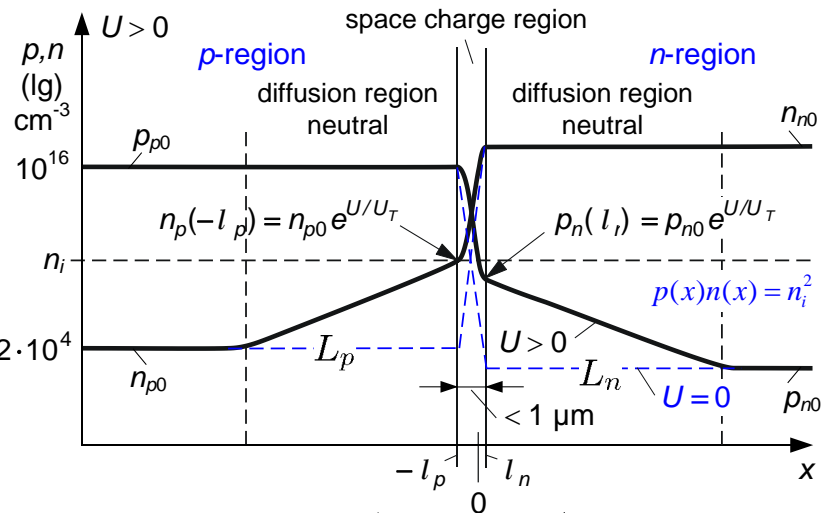


Band diagram, quasi Fermi levels  $W_{F_n,p}$





# Abrupt pn-Homojunction — Radiative / Nonradiative Recombinat.



Recombination described by minorities' lifetimes  $\tau_{n,p}$  in  $(p, n)$ -semiconductor (diffusion constants  $D_{n,p}$ , diffusion lengths  $L_{n,p}$ , electron  $n$  and hole concentration  $p$ ):

$$\tau_{n,p} = \frac{L_{n,p}^2}{D_{n,p}}, \quad \tau_{n\text{ sp, ns}}^{-1} = \frac{\partial r_{\text{sp, ns}}}{\partial n_{T,p}}$$

**Radiative recomb.** (rate  $r_{\text{sp}}$ , unit  $\text{cm}^{-3} \text{s}^{-1}$ ) of electrons and holes:

$$r_{\text{sp}} = B n_{T,p}, \quad B = \begin{cases} 1 \times 10^{-10} \dots 7 \times 10^{-10} \text{ cm}^3 \text{ s}^{-1} & \text{(Ga,Al)As} \\ 8.6 \times 10^{-11} \text{ cm}^3 \text{ s}^{-1} & \text{(In,Ga)(As,P)} \\ 3 \times 10^{-15} \text{ cm}^3 \text{ s}^{-1} & \text{Si (indirect SC)} \end{cases}$$

**Nonrad. recomb.** (rate  $r_{\text{ns}}$ , unit  $\text{cm}^{-3} \text{s}^{-1}$ ): Localized impurities, rate  $r_{\ell\text{S}}$  (Shockley-Read-Hall, SRH). Recomb. energy transferred to  $e$  or  $h$ , rate  $r_{\text{Au}}$ , (Auger, in  $(\text{In,Ga})(\text{As,P}) \rightarrow h$ , not in  $(\text{Ga,Al})\text{As}$ ):

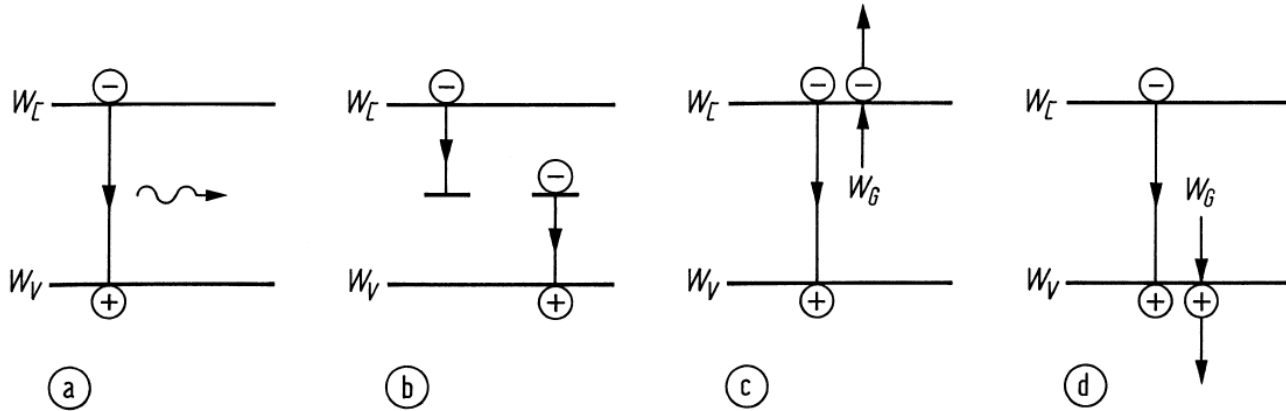
$$r_{\text{ns}} = r_{\ell\text{S}} + r_{\text{Au}}, \quad r_{\ell\text{S}} = A n_T, \quad r_{\text{Au}} = C n_{T,p}^2$$



# LECTURE 10



# Radiative and Nonradiative Recombination



*p*-Si rad. lifetime

$$p_p = 10^{16} \text{ cm}^{-3}:$$

$$\tau_{n\text{sp}}^{-1} = \frac{\partial r_{\text{sp}}}{\partial n_{T\text{p}}}$$

$$\tau_{n\text{sp}} = 33 \text{ ms}$$

o3e

Radiative and nonradiative transitions. (a) Radiative band-band transition. (b) Nonradiative transition via localized states in the forbidden band. (c) (d) Nonradiative Auger recombinations (recombination energy excites an electron in the CB or in the VB)

**Radiative recomb.** (rate  $r_{\text{sp}}$ , unit  $\text{cm}^{-3} \text{ s}^{-1}$ ) of electrons and holes:

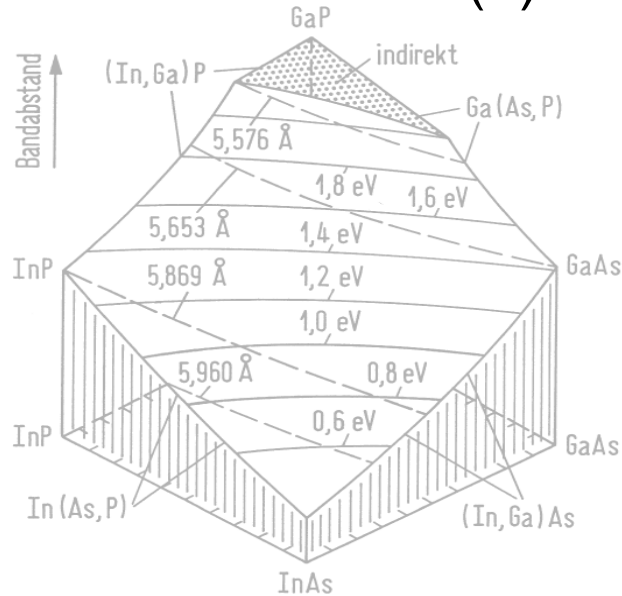
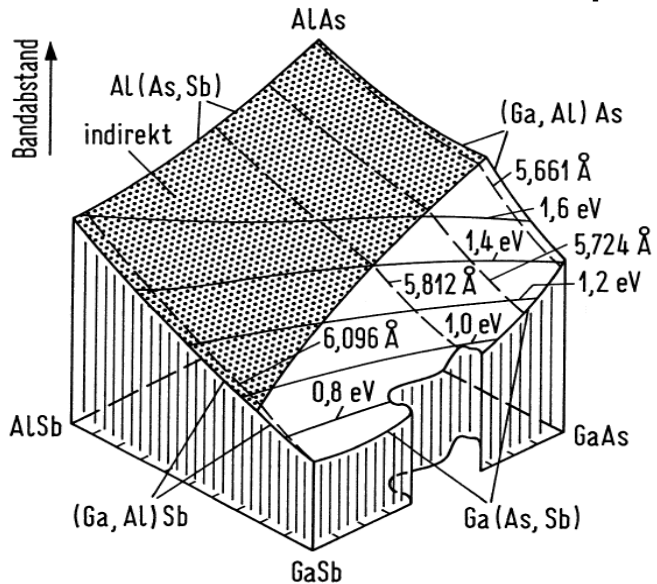
$$r_{\text{sp}} = B n_{T\text{p}}, B = \begin{cases} 1 \times 10^{-10} \dots 7 \times 10^{-10} \text{ cm}^3 \text{ s}^{-1} & (\text{Ga,Al})\text{As} \\ 8.6 \times 10^{-11} \text{ cm}^3 \text{ s}^{-1} & (\text{In,Ga})(\text{As,P}) \\ 3 \times 10^{-15} \text{ cm}^3 \text{ s}^{-1} & \text{Si (indirect SC)} \end{cases}$$

**Nonrad. recomb.** (rate  $r_{\text{ns}}$ , unit  $\text{cm}^{-3} \text{ s}^{-1}$ ): Localized impurities, rate  $r_{\ell\text{S}}$  (Shockley-Read-Hall, SRH). Recomb. energy transferred to *e* or *h*, rate  $r_{\text{Au}}$ , (Auger, in (In,Ga)(As,P) → *h*, not in (Ga,Al)As):

$$r_{\text{ns}} = r_{\ell\text{S}} + r_{\text{Au}}, \quad r_{\ell\text{S}} = A n_{T\text{p}}, \quad r_{\text{Au}} = C n_{T\text{p}}^2$$



# Compound Semiconductors (1)

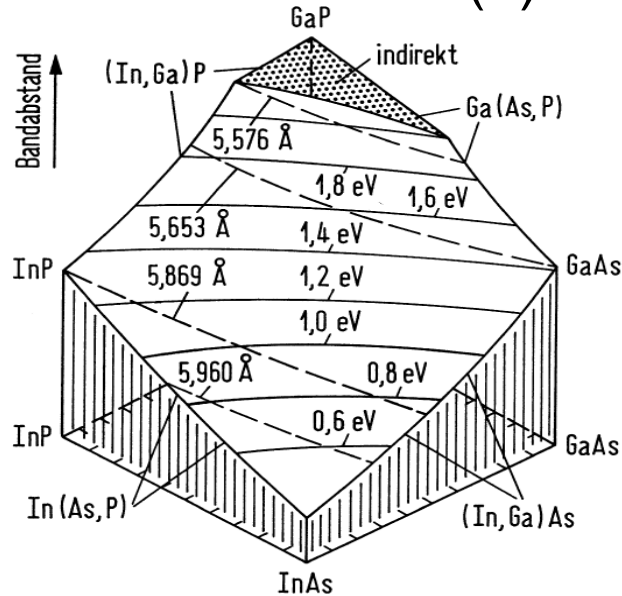
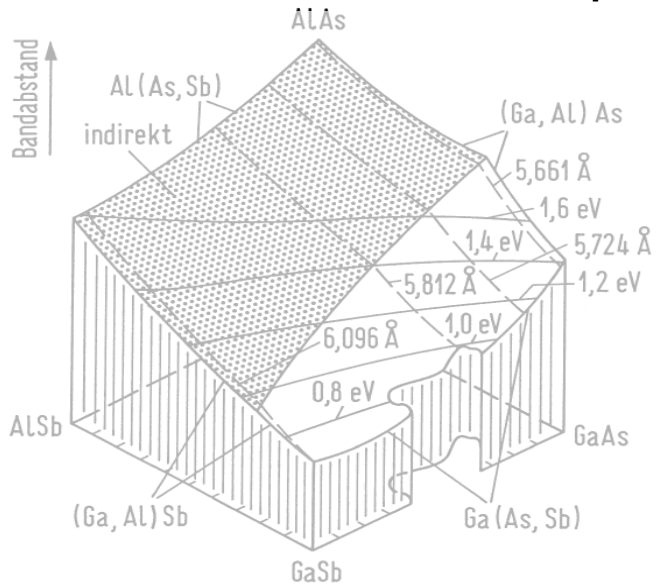


Semiconductor	$W_G$ / eV ( $\lambda_G$ / $\mu\text{m}$ )	$n$ at $\lambda_G$	$a$ / $\text{Å}$
GaSb, direct	0.726 (1.708)	3.82	6.096
GaAs, direct	1.424 (0.871)	3.655	5.653
AlSb, indirect	1.58 (0.785)	3.4	6.135
AlAs, indirect	2.163 (0.573)	3.178	5.660
$(\text{Ga}_{1-x}\text{Al}_x)\text{As}$ direct: $x \leq 0.3$	$1.424 + 1.247x$ $1.424 \dots 1.798$ ( $0.871 \dots 0.69$ )	$3.59 - 0.71x +$ $+0.091x^2$ (at $\lambda = 0.9 \mu\text{m}$ )	$5.653 + 0.027x$
$(\text{Ga}_{1-x}\text{Al}_x)(\text{As}_y\text{Sb}_{1-y})$ lattice-matched to GaSb direct: $x \leq 0.24$ $y = x/1.11$	$0.726 + 0.834x +$ $+1.134x^2$ $0.726 \dots 0.991$ ( $1.708 \dots 1.25$ )	?	6.096

**Table 3.1.** Material system  $(\text{Ga}_{1-x}\text{Al}_x)(\text{As}_y\text{Sb}_{1-y})$ .  $W_G$  bandgap,  $\lambda_G = hc/W_G$  bandgap wavelength,  $n$  refractive index,  $a$  lattice constant



# Compound Semiconductors (2)



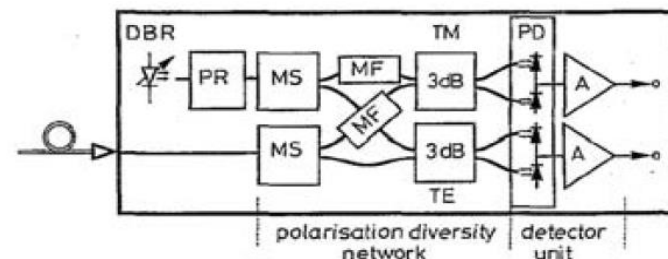
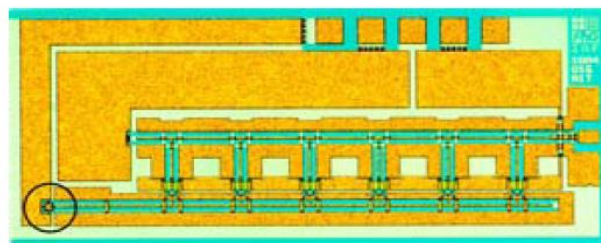
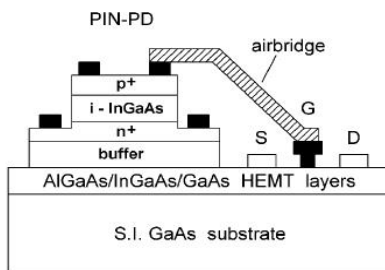
Semiconductor	$W_G / \text{eV}$ ( $\lambda_G / \mu\text{m}$ )	$n$ at $\lambda_G$	$a / \text{Å}$
InAs, direct	0.36 (3.444)	3.52	6.058
InP, direct	1.35 (0.918)	3.45	5.869
GaAs, direct	1.424 (0.871)	3.655	5.653
GaP, indirect	2.261 (0.548)	3.452	5.451
$(\text{In}_{0.49}\text{Ga}_{0.51})\text{P}$ , direct lattice-matched to GaAs	1.833 (0.676)	3.451 ?	5.653
$(\text{In}_{0.53}\text{Ga}_{0.47})\text{As}$ , direct lattice-matched to InP	0.75 (1.653)	3.61	5.869
$(\text{In}_{1-x}\text{Ga}_x)(\text{As}_y\text{P}_{1-y})$ lattice-matched to InP direct: $y \leq 1$ $x = y / (2.2091 - 0.06864 y)$	$1.35 - 0.72 y + 0.12 y^2$ 0.36 ... 0.75 (0.918 ... 1.653)	$3.45 + 0.256 y - 0.095 y^2$ 3.45 ... 3.61	5.869

**Table 3.2.** Material system  $(\text{In}_{1-x}\text{Ga}_x)(\text{As}_y\text{P}_{1-y})$ .  $W_G$  bandgap,  $\lambda_G = hc/W_G$  bandgap wavelength,  $n$  refractive index,  $a$  lattice constant





# Opto-Electronic Integrated Circuits



(a) InGaAs PIN photodiode on GaAs. Air bridge to HEMT amplifier<sup>17</sup>

(b) Photodiode (○) with 30 Ω coplanar transmission lines and 6 interconnecting cascaded HEMT<sup>17</sup>

(c) Polarization diversity heterodyne receiver integrated on InP substrate with local laser, couplers, detectors, and electronics<sup>18</sup>

**Fig. 3.5.** Advanced OEIC designs. (a) Top-illuminated ( $\text{In}_{0.53}\text{Ga}_{0.47}$ )As pin photodiode on a semi-insulating (S.I.) GaAs substrate. Diameter of light-sensitive area  $10\ \mu\text{m}$ , sensitivity  $S = 0.4\ \text{A/W}$ , dark current  $9\ \text{nA}$  at  $-2\ \text{V}$  bias (b) 40 Gbit, 6-stage travelling wave amplifier, HEMT gate length  $0.15\ \mu\text{m}$ . Processing time 3 months, chip size  $2.5\ \text{mm} \times 1\ \text{mm}$  on a 3-in wafer (c) Optical polarization diversity heterodyne receiver with tunable local distributed Bragg reflector laser (DBR), polarization rotator (PR), mode splitters (MS), mode filters (MF), 3 dB couplers, photodiodes (PD), and electronic amplifiers (A) consisting of JFET and load resistors. Processing time 5 months, 25 mask steps, 7 epitaxy steps, 170 main processing steps, 2 in wafer, 100 receiver chips  $9\ \text{mm} \times 0.6\ \text{mm}$ , carrying 17 sub-components, yield  $> 50\%$

Examples of early opto-electronic integrated circuits (OEIC):

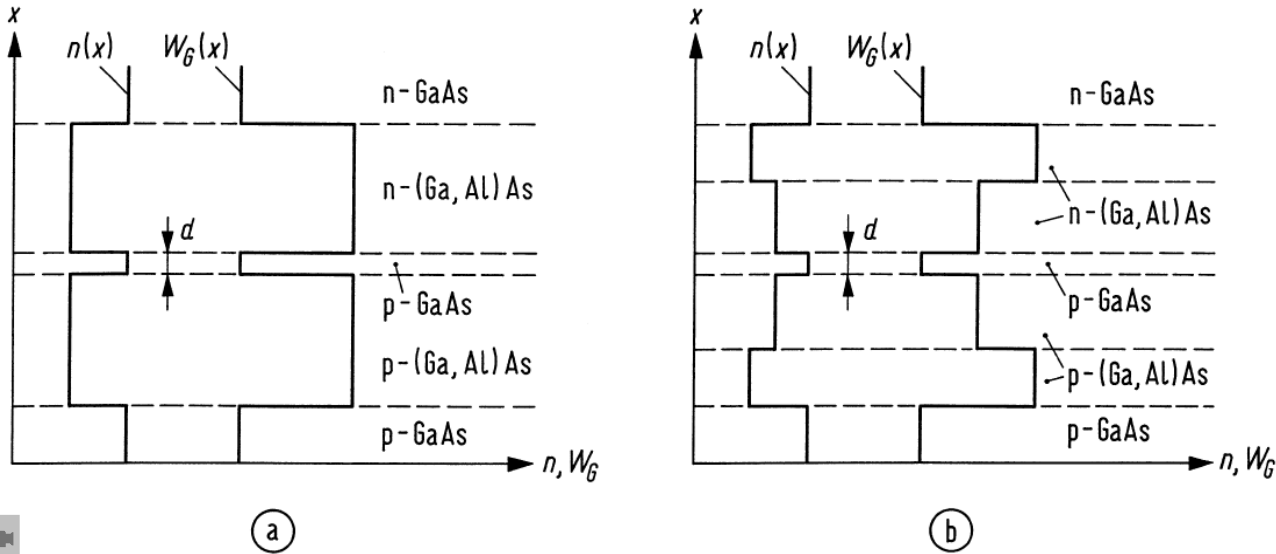
**GaAs** Hybridly integrated 40 Gbit/s pin HEMT receiver (1998).

**InP** Monolithically integrated optical heterodyne receiver with tunable local distributed feedback (DFB) laser, polarization diversity reception and detector unit (1994).





# Heterojunctions



**Fig. 3.11.** Schematic refractive index dependence  $n$  and bandgap  $W_G$  as a function of the spatial coordinate  $x$  in  
 a (a) 3-layer heterostructure, (b) 5-layer heterostructure

“Isotype” if semiconductors have same conduction type.

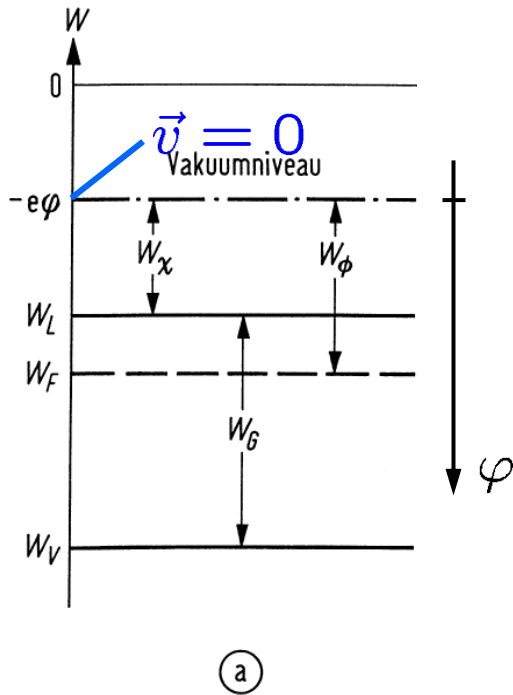
“Anisotype” if conduction type differs.

Conduction type with small letters n, i, p if semiconductor has smaller bandgap than neighbour, and with capital letters N, I, P if bandgap is larger.

Fig. 3.11(a) from top: nN, Np, pP and Pp



# Band Diagram for Heterostructures



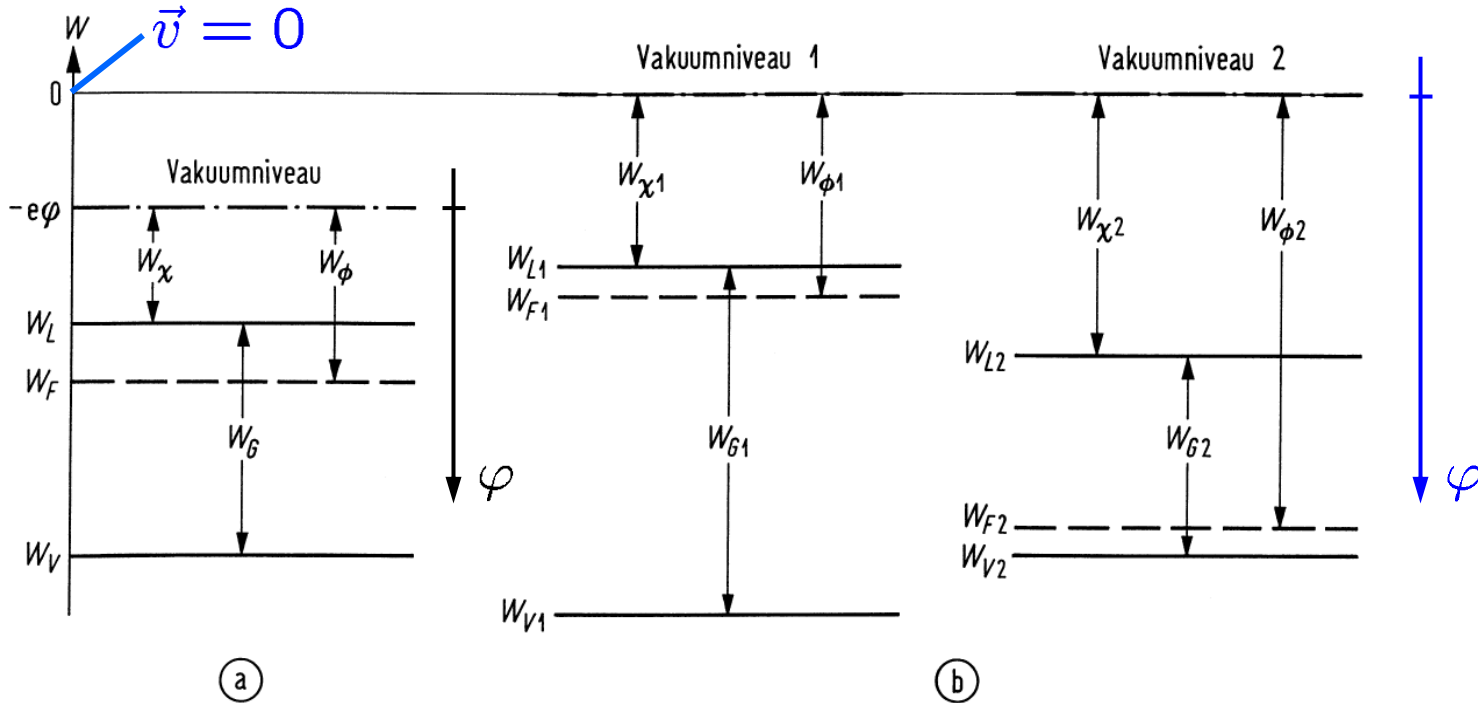
(a)

**Fig. 3.12.** Energy scale for electrons in a semiconductor. (a) Semiconductor at potential  $\varphi \neq 0$ . (b) Two independent, insulated semiconductors at potential  $\varphi = 0$  with different bandgaps.  $W_\chi$  electron affinity,  $W_\phi$  work function.  $W_L$  conduction band edge ( $\hat{=}$   $W_C$ , Vakuumniveau  $\hat{=}$  vacuum level)

$e$  leaving at  $\vec{v} = 0$  are at vacuum level  $W = -e\varphi$ .  $e$ -affinity  $W_\chi$ , work function  $W_\phi$ .  $W_G = W_C - W_V$ ,  $W_\chi$ ,  $W_\phi$  fix distances of CB edge, Fermi level, VB edge wrt vacuum level.



# Band Diagram for Heterostructures

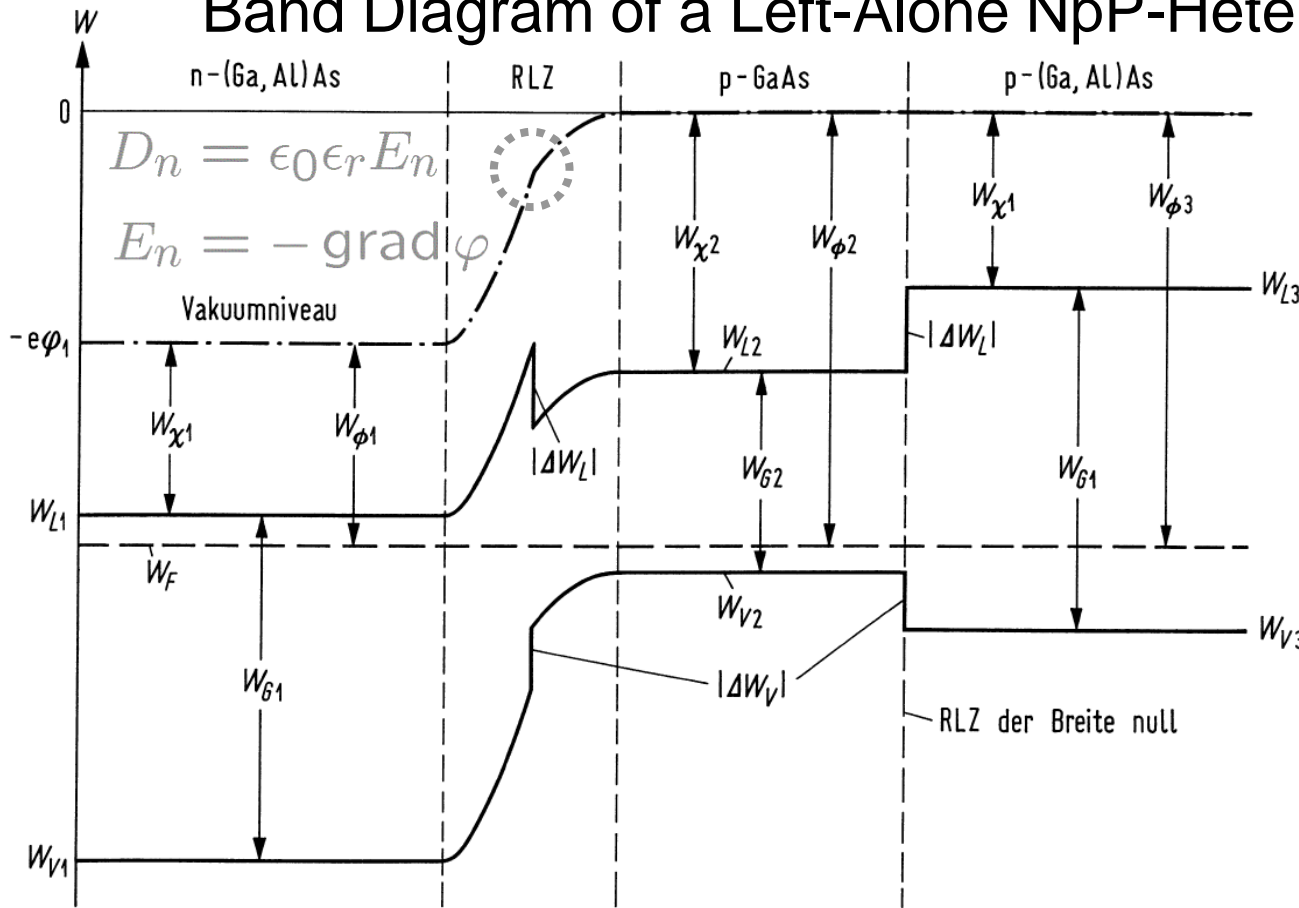


**Fig. 3.12.** Energy scale for electrons in a semiconductor. (a) Semiconductor at potential  $\varphi \neq 0$ . (b) Two independent, insulated semiconductors at potential  $\varphi = 0$  with different bandgaps.  $W_\chi$  electron affinity,  $W_\phi$  work function.  $W_L$  conduction band edge ( $\hat{=} W_C$ , Vakuumniveau  $\hat{=} vacuum level$ )

$e$  leaving at  $\vec{v} = 0$  are at vacuum level  $W = -e\varphi$ .  $e$ -affinity  $W_\chi$ , work function  $W_\phi$ .  $W_G = W_C - W_V$ ,  $W_\chi$ ,  $W_\phi$  fix distances of CB edge, Fermi level, VB edge wrt vacuum level.



# Band Diagram of a Left-Alone NpP-Heterojunction



Shallow saturated impurities,  $n_{T1} = n_D$ ,  $p_2 = n_A$

**Homojunction:**

Diffusion voltage or built-in potential  $U_D$  (thermal voltage  $U_T$ )

**Effective DOS:**

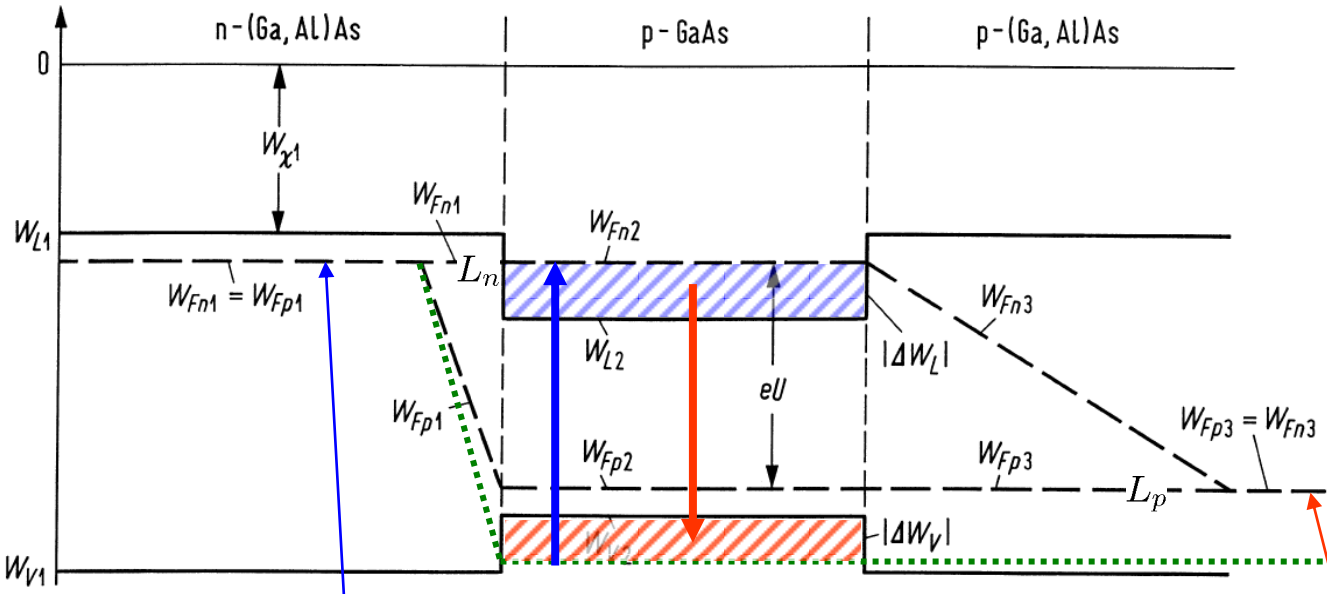
$$N_B = 2 \left( \frac{2\pi |m_{\text{eff}}| kT}{h^2} \right)^{\frac{3}{2}}$$

**Fig. 3.13.** Energy-band diagram of a double-heterostructure with anisotype Np-junction and a special isotype pP-junction with diffusion voltage zero ( $W_L \hat{=} W_C$ , Leitungsband  $\hat{=}$  conduction band, Vakuumniveau  $\hat{=}$  vacuum level, Raumladungszone RLZ der Breite null  $\hat{=}$  space-charge region of zero width)

$$\varphi_1 = U_D = U_T \ln \frac{n_D n_A}{n_i^2}, \quad U_T = \frac{kT}{e}, \quad W_G = -kT \ln \frac{n_i^2}{N_C N_V}$$



# Band Diagram of a Forward-Biased NpP-Heterojunction



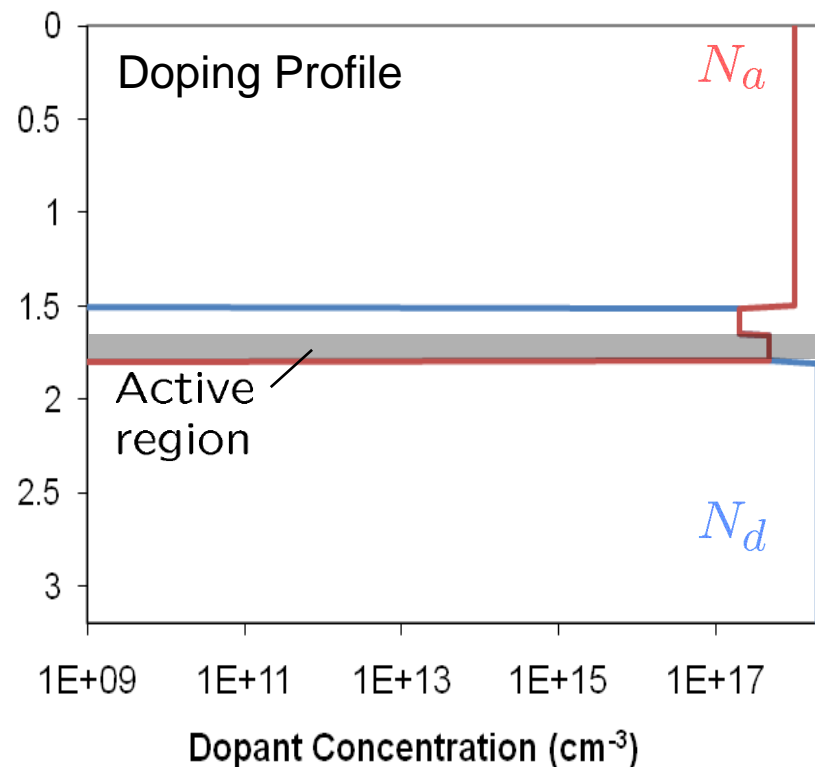
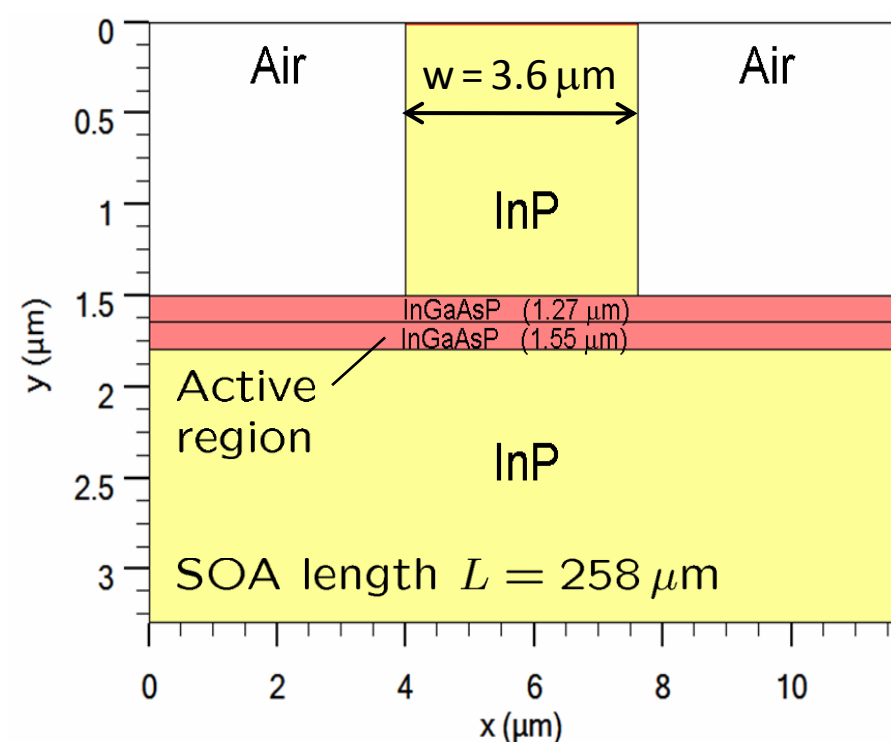
Practical for  $T > 0$ .  
Simpler for  $T = 0$ :

**Fig. 3.14.** Energy-band diagram of a NpP-heterojunction of Fig. 3.13 with a forward bias voltage.  $L_p/L_n \approx 0.2$  for GaAs ( $W_L \hat{=} W_C$ )

Far away from junction, quasi Fermi levels of  $e, h$  unchanged. Inside thin p-GaAs layer and DZ,  $W_{Fn} > W_{Fp}$  due to carrier injection.  $L_n > L_p \rightarrow p$ -DZ larger than  $n$ -DZ. GaAs:  $L_n/L_p = 5$ .  $e, h$  confined to potential well inside p-GaAs layer. Quasi Fermi level  $W_{Fn}$  moved into CB.  $\rightarrow hf^{(a)} \geq W_{Fn} - W_{Fp} = eU \rightarrow W_G < hf^{(e)} \leq eU$



# Bulk SOA Structure for Doping Design Study at $\lambda = 1.55 \mu\text{m}$



Tendencies calculated\* *ab initio* with Silvaco ATLAS (modified for simulating SOA). Use of well-characterized† bulk-SOA for checking relevance of simulation results.

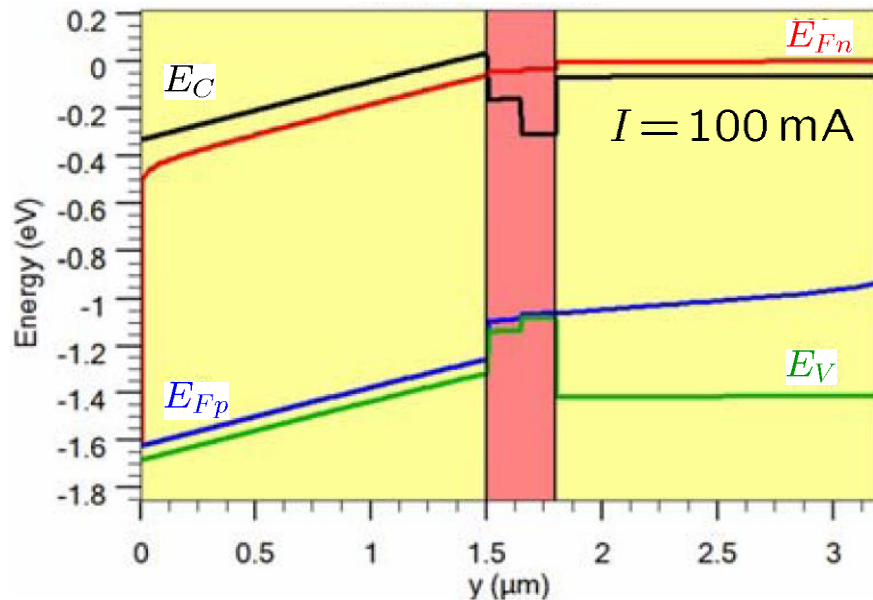
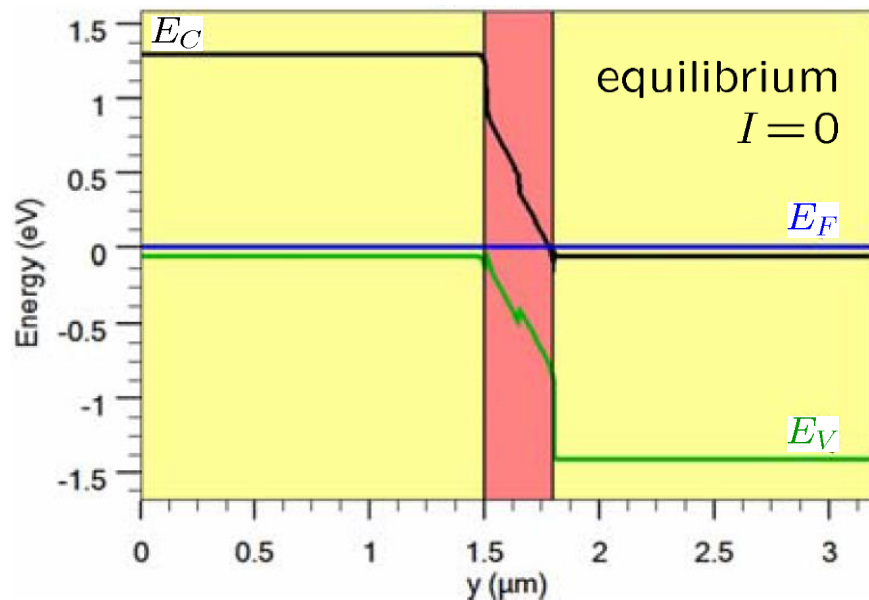
\* Kapoor, A.; Sharma, E. K.; Freude, W.; Leuthold, J.: Investigation of the saturation characteristics of InGaAsP-InP bulk SOA. Photonics West 2010. Paper 7597-56

† Leuthold, J.: Advanced indium-phosphide waveguide Mach-Zehnder interferometer all-optical switches and wavelength converters. Konstanz: Hartung-Gorre 1999





# Bulk SOA — Trends for Doping the Active Region ( $\lambda = 1.55 \mu\text{m}$ )



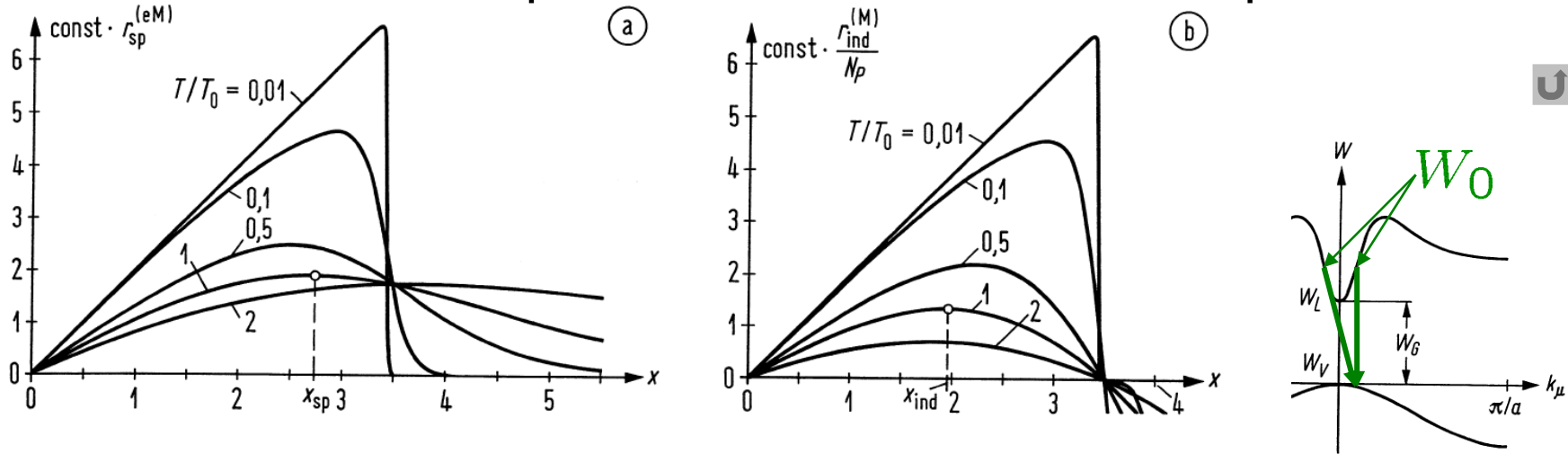
$p$ -doping ( $n$ -doping) shifts quasi-Fermi level  $E_{Fp}$  more into (away from) the valence band  $\rightarrow$  increases (decreases) small-signal gain constant  $g_0$  and differential gain  $a \rightarrow$  decreases (increases)  $P_{\text{sat}}^{\text{in}}$ :

$$P_{\text{in}}^{\text{sat}} = \frac{2 \ln 2}{G_0 - 2} h f \frac{A/\Gamma}{a \tau_e}, \quad G_0 = e^{\Gamma g_0 L} \quad P_{\text{sat}}^{\text{in}} \downarrow \quad P_{\text{sat}}^{\text{in}} \uparrow$$

However, there are other influences:  $a$  &  $\tau_e$  (besides  $\Gamma$  &  $L$ )!



# Emission and Absorption in a Semiconductor. Amplification



**Fig. 3.15.** Frequency dependence of spontaneous and induced emission for various temperatures  $T/T_0 = 0.01, 0.1, 0.5, 1, 2$  ( $T_0$  reference temperature;  $W_{Fn} - W_C$  and  $W_V - W_{Fp}$  are kept constant to  $3kT_0$  and  $0.5kT_0$ , respectively;  $m_n/m_p = 0.14$  as in GaAs). Normalized frequency  $x = (hf - W_G)/(kT_0)$ . (a) Spontaneous emission and (b) induced emission per photon, Eq. (3.44). The multiplicative constant is identical in both diagrams.

$$r_{\text{ind}}^{(\text{M})} = r_{\text{ind}}^{(\text{eM})} - r_{\text{ind}}^{(\text{aM})}$$

$$\sim N_P [f_C(W_0) - f_V(W_0 - hf)],$$

$$r_{\text{sp}}^{(\text{eM})} \sim f_C(W_0) [1 - f_V(W_0 - hf)],$$

$$W_0 = W_C + \frac{\hbar^2 k_{\mu 0}^2}{2m_n}$$

**Gain rate:**

$$\left. \begin{aligned} r_{\text{ind}}^{(\text{M})} &= \frac{1}{V} \frac{dN_P}{dt} \\ G &= \frac{1}{N_P} \frac{dN_P}{dt} \end{aligned} \right\} G = \frac{r_{\text{ind}}^{(\text{M})}}{N_P/V}$$

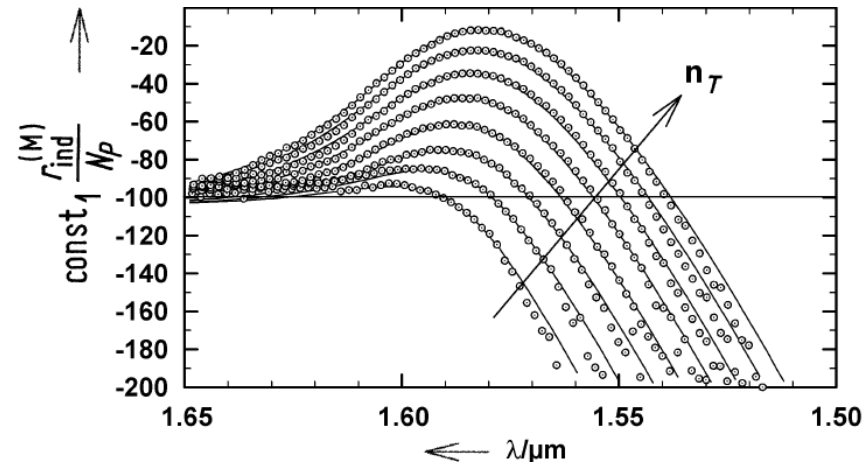


# LECTURE 11



# Emission and Absorption in a Semiconductor. Measurement

Measured wavelength dependence of induced emission per photon for various carrier densities  $n_T$ . The multiplicative constant is different from Fig. 3.15



$$r_{\text{ind}}^{(M)} = r_{\text{ind}}^{(eM)} - r_{\text{ind}}^{(aM)}$$

$$\sim N_P [f_C(W_0) - f_V(W_0 - hf)],$$

$$r_{\text{sp}}^{(eM)} \sim f_C(W_0) [1 - f_V(W_0 - hf)],$$

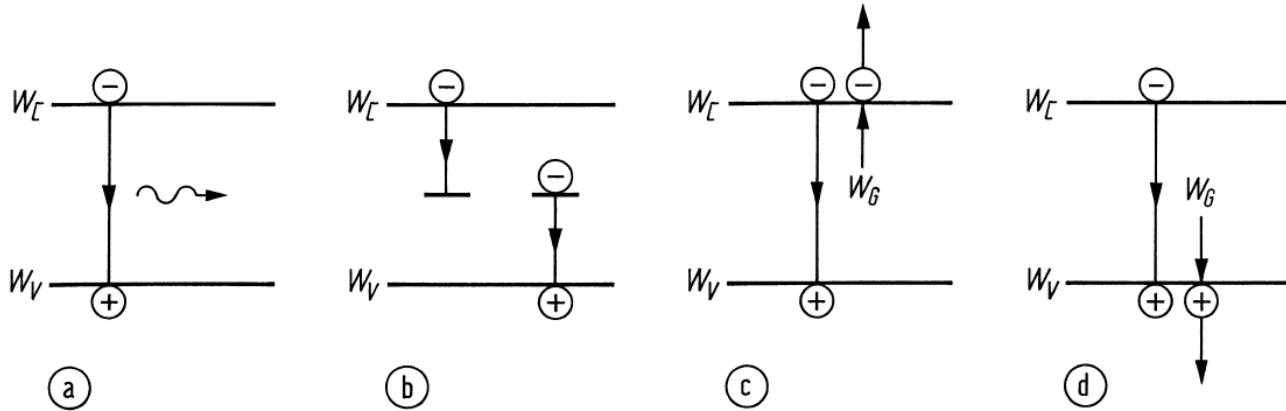
$$W_0 = W_C + \frac{\hbar^2 k_{\mu 0}^2}{2m_n}$$

Gain rate:

$$\left. \begin{aligned} r_{\text{ind}}^{(M)} &= \frac{1}{V} \frac{dN_P}{dt} \\ G &= \frac{1}{N_P} \frac{dN_P}{dt} \end{aligned} \right\} G = \frac{r_{\text{ind}}^{(M)}}{N_P/V}$$



# Radiative and Nonradiative Recombination



*p*-Si rad. lifetime

$$p_p = 10^{16} \text{ cm}^{-3}:$$

$$\tau_{n\text{sp}}^{-1} = \frac{\partial r_{\text{sp}}}{\partial n_T}$$

$$\tau_{n\text{sp}} = 33 \text{ ms}$$

Radiative and nonradiative transitions. (a) Radiative band-band transition. (b) Nonradiative transition via localized states in the forbidden band. (c) (d) Nonradiative Auger recombinations (recombination energy excites an electron in the CB or in the VB)

**Radiative recomb.** (rate  $r_{\text{sp}}$ , unit  $\text{cm}^{-3} \text{ s}^{-1}$ ) of electrons and holes:

$$r_{\text{sp}} = B n_T p, B = \begin{cases} 1 \times 10^{-10} \dots 7 \times 10^{-10} \text{ cm}^3 \text{ s}^{-1} & \text{(Ga,Al)As} \\ 8.6 \times 10^{-11} \text{ cm}^3 \text{ s}^{-1} & \text{(In,Ga)(As,P)} \\ 3 \times 10^{-15} \text{ cm}^3 \text{ s}^{-1} & \text{Si (indirect SC)} \end{cases}$$

**Nonrad. recomb.** (rate  $r_{\text{ns}}$ , unit  $\text{cm}^{-3} \text{ s}^{-1}$ ): Localized impurities, rate  $r_{\ell\text{S}}$  (Shockley-Read-Hall, SRH). Recomb. energy transferred to  $e$  or  $h$ , rate  $r_{\text{Au}}$ , (Auger, in (In,Ga)(As,P)  $\rightarrow h$ , not in (Ga,Al)As):

$$r_{\text{ns}} = r_{\ell\text{S}} + r_{\text{Au}}, \quad r_{\ell\text{S}} = A n_T, \quad r_{\text{Au}} = C n_T p^2$$



# Effective Carrier Recombination Lifetime. Step Response

Effective recombination rate:

$$r_{\text{eff}} = r_{\text{sp}} + r_{\text{ns}} = r_{\text{sp}} + r_{\ell\text{S}} + r_{\text{Au}}$$

In diode recombination zone (layer height  $d$ , cross-section area  $F$ ) carrier density changes if injected carrier rate (injection current density  $J$ , elementary charge  $e$ ) deviates from recombination rate:

$$\frac{dn_T}{dt} = \frac{J}{ed} - r_{\text{eff}}(n_T)$$

Strictly speaking,  $r_{\text{eff}}(n_T) \rightarrow r_{\text{eff}}(n_T) - r_{\text{eff}}(n_{T\text{eq}})$  for correct solution at concentration  $n_{T\text{eq}}$  for thermal equilibrium  $J = 0$ .

Step perturbation  $J \rightarrow J_0 + J_1$ . Perturbation ansatz  $n_T(t) = n_{T0} + n_{T1}(t)$ , series expansion  $r_{\text{eff}} = r_{\text{eff}0} + (\partial r_{\text{eff}}/\partial n_T)n_{T1}$  at  $n_{T0}$ :

$$n_{T1}(t) = \frac{J_1 \tau_{\text{eff}}}{ed} \left(1 - e^{-t/\tau_{\text{eff}}}\right), \quad \text{with} \quad \tau_{\text{eff}}^{-1} = \frac{\partial r_{\text{eff}}}{\partial n_T}$$





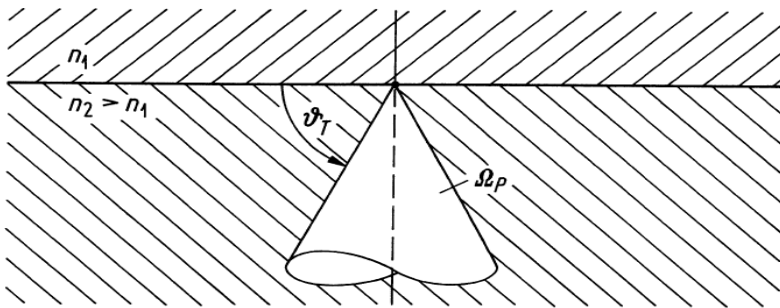
# LED — Generated Power, Internal and Optical Efficiency

Light-emitting diodes (LED) without end mirrors, spontaneous emission rate  $r_{sp}^{(eM)}$  dominates. Double-heterostructures common. Generated light power  $P$ :

$$P = \frac{n_T F d \cdot h f}{\tau_{sp}} = \eta_{int} h f \frac{I}{e}, \quad \eta_{int} = \frac{\tau_{eff}}{\tau_{sp}} = \frac{P/(h f)}{I/e}$$

Isotropic emission into  $4\pi$ . Fraction  $(1 - R_P) \Omega_P / (4\pi)$  (TIR solid angle  $\Omega_P$ , cone semi-angle  $\pi/2 - \vartheta_T$ ) into medium  $n_1 < n_2$  (GaAs):

$$n_1 \cong \text{air (silica):} \quad \eta_{opt} = \frac{\Omega_P}{4\pi} (1 - R_P) = 1.5 \% \quad (3.5 \%)$$



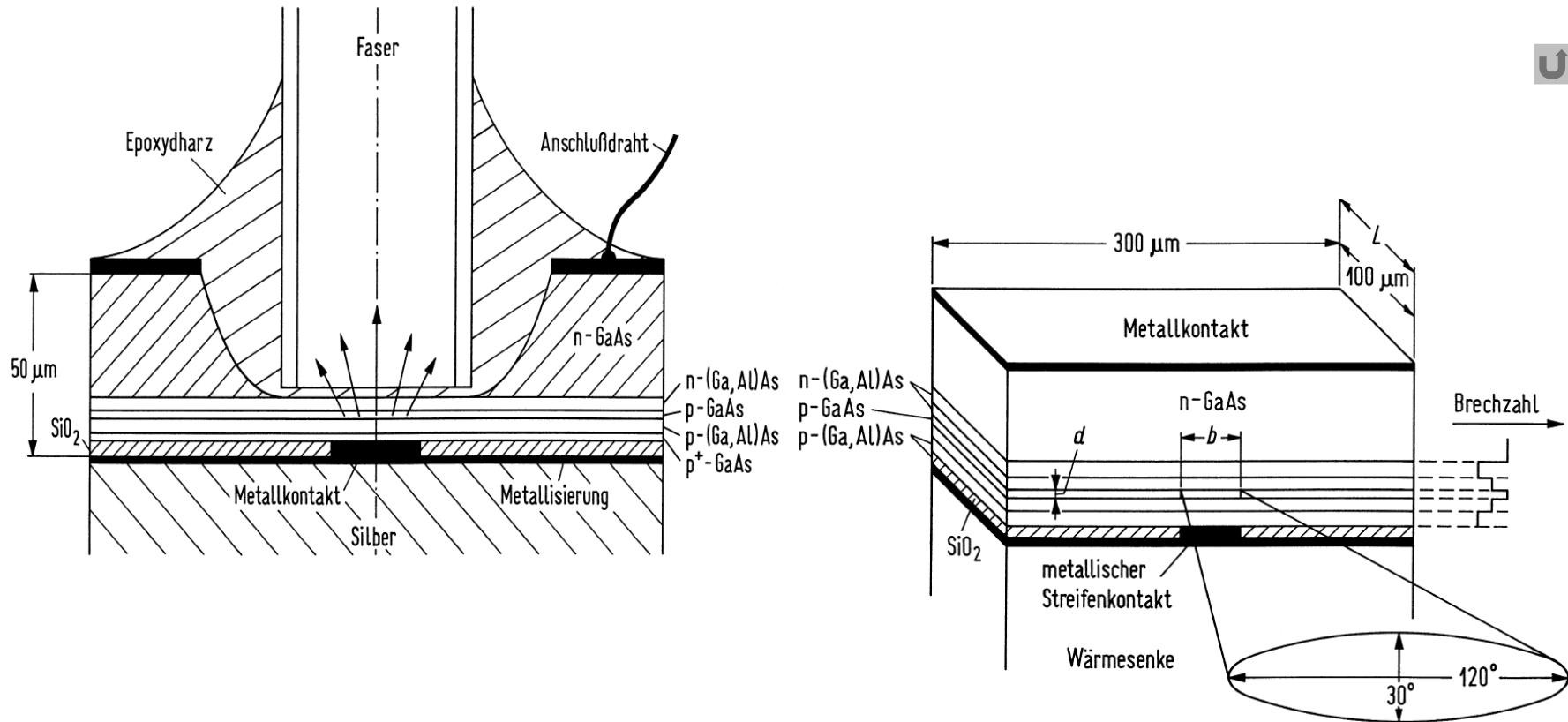
$$\left\{ \begin{array}{l} \Omega_P = 2\pi(1 - \sin \vartheta_T) = 0.27 \text{ sr} \quad (0.54 \text{ sr}) \\ \cos \vartheta_T = n_1/n_2 = 73^\circ \quad (66^\circ) \\ R_P = \left( \frac{n_1 - n_2}{n_1 + n_2} \right)^2 = 32 \% \quad (18 \%) \end{array} \right.$$

Plane boundary between two media ( $n_1, n_2 > n_1$  refractive indices,  $\vartheta_T$  critical angle of total reflection,  $R_P$  power reflection factor). Only the fraction  $(1 - R_P)$  of the radiation from the solid angle  $\Omega_P$  is transmitted into the medium  $n_1$ .



# LED — Device Structure. Surface and Edge Emitter, SLED

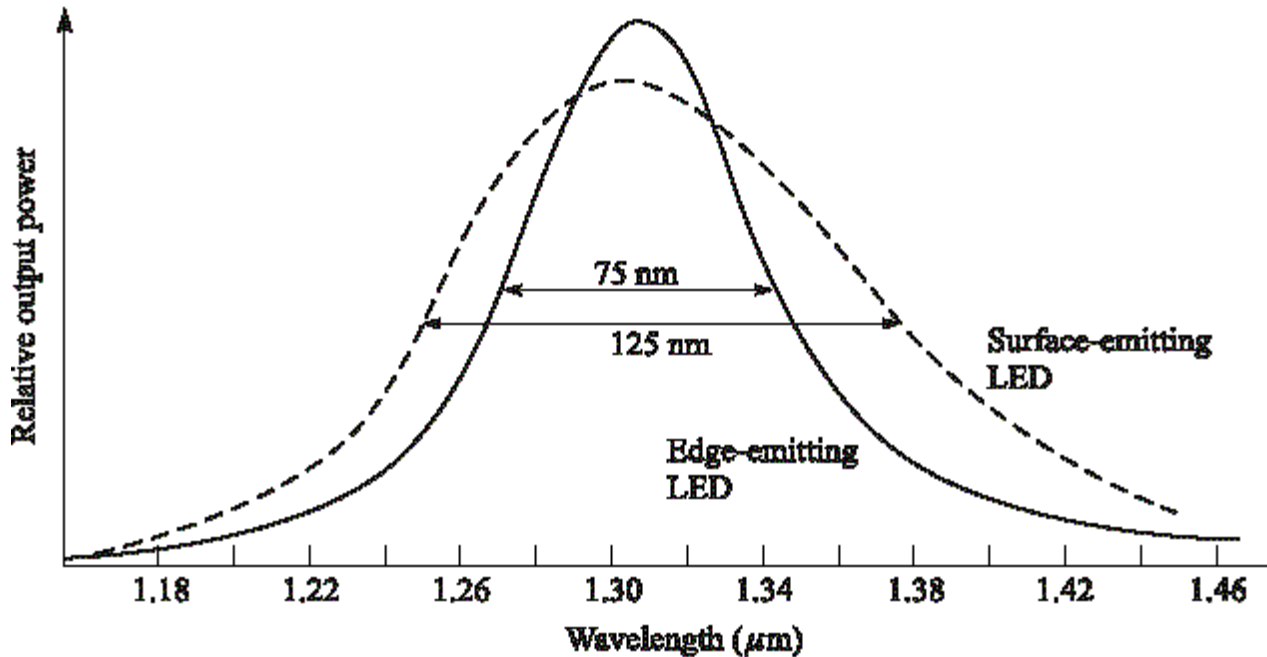
Small-area high-radiance (Ga,Al)As double-heterostructure surface-emitter LED with attached fibre (Burrus diode). Epoxydharz = epoxy resin, Anschlußdraht = bond wire, Metallkontakt = metal contact, Metallisierung = metallization



**Fig. 3.20.** Edge-emitting double-heterostructure LED.  $L$ ,  $b$ ,  $d$  are length, width and thickness of the active zone. Metallkontakt = metal contact, metallischer Streifenkontakt = metallic contact strip, Wärmesenke = heat sink, Brechzahl = refractive index



# LED — Power Spectrum



Photons emitted in spectral range  $W_G \leq hf \leq (W_C + 2kT_0) - W_V$ .  
 Total spectral emission width  $h \Delta f_H = 2kT_0$ :

$$h \Delta f_H = 2kT_0 = 50 \text{ meV}, \quad \Delta f_H = 12.1 \text{ THz} \quad \text{RT } T_0 = 293 \text{ K}$$

**GaAs:**  $\Delta\lambda_H = 30 \text{ nm}$ . **(In,Ga)(As,P):**  $\Delta\lambda_H = 70 \text{ nm}$  at  $\lambda = 1.3 \mu\text{m}$ .  
 $\Delta f_{\text{gain}}$  also estimates amplification bandwidth of semiconductor laser devices. Corresponds to width  $\Delta f_H$  of lineshape  $\rho(f)$ .



# LD — Cavity and Field Confinement

Conventional laser diode (LD) has rectangular cavity → Fabry-Perot (FP) resonator → Fabry-Perot laser diode (FP LD). Structure similar to LED edge-emitter.

Laser-active volume  $V = dbL$  dimensions  $d = 0.1 \dots 0.2 \mu\text{m}$  (vertical,  $x$ -axis),  $b = 2 \dots 5 \mu\text{m}$  (lateral,  $y$ -axis),  $L = 300 \dots 1200 \mu\text{m}$ , (longitudinal,  $z$ -axis).

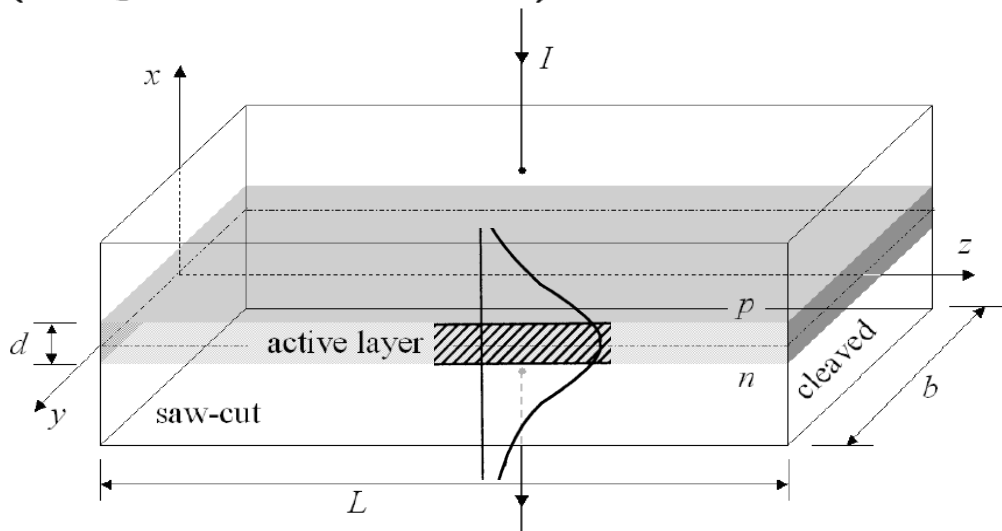
Field confinement:

$$\Gamma_{\text{TE}} = \frac{\int_{-d/2}^{+d/2} |E_y(x)|^2 dx}{\int_{-\infty}^{+\infty} |E_y(x)|^2 dx}$$

LD:  $\Gamma_{\text{TE}}(\text{TM}) = .184 (.145)$

SOA: .3 (.25)      LD → TE

$d = .1 \rightarrow .2 \mu\text{m}$ :  $\Gamma = .2 \rightarrow .6$



**Fig. 3.6.** Forward biased semiconductor pn-homojunction acting as a laser diode. Side-walls are saw-cut, the end facets are cleaved. Typical dimensions:  $d = 0.1 \dots 0.2 \mu\text{m}$  (active layer),  $b = 3 \dots 6 \mu\text{m}$ ,  $L = 200 \dots 600 \mu\text{m}$



# LD — Longitudinal Mode Spectrum

Transverse WG mechanism described by  $\beta/k_0 = n_e < n$ . Subscript  $e$  dropped.

Equivalent plane waves propagating along  $z$ -axis ( $k_{x,y} = 0, k_z = k$ ):

$$k \cdot 2L = k_0 n \cdot 2L = \omega n \cdot 2L / c = m_z \cdot 2\pi, \quad m_z = 1, 2, 3, \dots$$

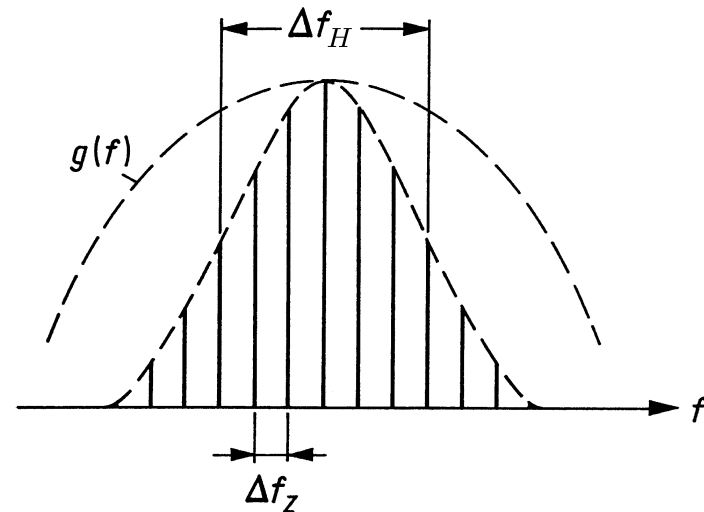
Regarding  $m_z$  as continuous:

$$\frac{d(fn)}{dm_z} = \frac{df}{dm_z} n + f \frac{dn}{df} \frac{df}{dm_z} = \frac{df}{dm_z} \left( n + f \frac{dn}{df} \right) = \frac{c}{2L}$$

$m_z$  discrete  $\rightarrow dm_z \rightarrow 1, df \rightarrow \Delta f_z$ .

Longitudinal mode spacing (free spectral range FSR, round-trip time  $\tau_U$ ):

$$\Delta f_z = \frac{c}{2n_g L} = \frac{v_g}{2L} = \frac{1}{\tau_U}$$



## LD — Gain and Loss

**Multi-moded resonator**, one mode considered. Modes replaced by plane waves with effective propagation properties, complex (effective) refractive index  $\bar{n} = n - j n_i$ , real part  $n$ , imaginary part  $-n_i$ . Subscript  $e$  dropped as before:

$$\exp(-j\bar{k}z), \quad \left\{ \begin{array}{l} \bar{k} = k_0\bar{n} = k + j\frac{1}{2}(g - \alpha_V), \\ \bar{n} = n - j n_i, \\ k_0 = \omega/c, \end{array} \right\}, \quad g - \alpha_V = -2k_0 n_i$$

**Modal power gain**  $g$  and loss constant  $\alpha_V$ . Corresponds to net effective gain rate  $\Gamma G$  due to band-band transitions and power loss time constant  $1/\tau_V$  not including band-band transitions.

**Localized mirror losses**  $\rightarrow$  power “gain”  $R_1 R_2 = \exp(-\alpha_{R1} 2L) \times \exp(-\alpha_{R2} 2L) = \exp(-\alpha_R 2L)$  distributed over round-trip time  $\tau_U$ . Constant gain rate per  $\tau_U \rightarrow$  net  $N_P$ -increase per second:

$$G - \frac{1}{\tau_P} = \frac{1}{N_P} \frac{dN_P}{dt}, \quad \frac{N_P(\tau_U)}{N_P(0)} = \exp\left[\left(G - \frac{1}{\tau_P}\right)\tau_U\right], \quad \tau_U = \frac{2L}{v_g}$$





# LECTURE 12



# Stationary Laser Oscillation

**Stationary laser oscillation** with angular frequency  $\omega_0$  for  $\Gamma G = 1/\tau_P \rightarrow$  modal gain compensates resonator losses. A *monochromatic* light wave makes a complete round-trip during  $t = \tau = 2nL/c$  without attenuation or phase shift:

$$\exp(j\omega_0\tau) \exp\left[\frac{1}{2}\left(\Gamma G - \frac{1}{\tau_P}\right)\tau\right] = 1,$$
$$\omega_0\tau = m_z \cdot 2\pi, \quad \tau = \frac{2nL}{c}, \quad m_z = 0, 1, 2, \dots, \quad \Gamma G = \frac{1}{\tau_P}$$

**Condition**  $\omega_0\tau = m_z \cdot 2\pi$  corresponds to longitudinal mode spacing  $\Delta f_z \rightarrow n_g$  is effective group refractive index.

**Modal gain rate**  $\Gamma G = \Gamma r_{\text{ind}}^{(M)} V/N_P$ . Total resonator loss rate  $1/\tau_P$  from finite mirror reflectivity  $R_{1,2}$  (photon loss rate  $1/\tau_{R1,2}$ , total loss rate  $1/\tau_R$ ), and from background resonator losses (photon loss rate  $1/\tau_V$ ):

$$\tau_P^{-1} = \tau_V^{-1} + \tau_R^{-1}, \quad \tau_R^{-1} = \tau_{R1}^{-1} + \tau_{R2}^{-1}.$$



# LD — Gain and Loss Distributed

Relations between gain rate and modal power gain:

$$\begin{aligned}\exp\left[(G - 1/\tau_P)\tau_U\right] &= \exp\left[(G - 1/\tau_V - 1/\tau_R)\tau_U\right] \\ &= R_1 R_2 \exp\left[(G - 1/\tau_V)\tau_U\right] \\ &= R_1 R_2 \exp\left[(G - 1/\tau_V)2L/v_g\right] \\ &= R_1 R_2 \exp\left[(g - \alpha_V)2L\right] \\ &= \exp\left[(g - \alpha_V - \alpha_R)2L\right] \\ &= \exp\left[(g - \alpha_V - \alpha_{R1} - \alpha_{R2})2L\right]\end{aligned}$$

Comparing:

$$\begin{aligned}G &= v_g g, \\ 1/\tau_V &= v_g \alpha_V, \\ 1/\tau_{R1,2} &= v_g \alpha_{R1,2} = -v_g \ln R_{1,2}/(2L), \\ 1/\tau_R &= v_g \alpha_R = -v_g \ln(R_1 R_2)/(2L), \\ 1/\tau_P &= v_g(\alpha_V + \alpha_R) = v_g[\alpha_V - \ln(R_1 R_2)/(2L)]\end{aligned}$$



## LD — Gain Model and Gain Compression



Laser oscillates near  $f_0$  (maximum spectral gain). Larger carrier number  $\rightarrow$  nonlinear gain compression  $\rightarrow$  energy states near  $hf_0$  deplete (hot carrier effects, spectral hole burning). Depleted states filled only in intraband relaxation time  $\tau_{CB}$   $\rightarrow$  “bottleneck” for carrier number available near  $hf_0$ .

Nonlinear gain compression modeled with gain compression factor  $\varepsilon_G$ , differential gain  $G_d$ , transparency concentration  $n_t$ :

$$G(n_T, N_P) = \frac{G(n_T)}{1 + \varepsilon_G \frac{\Gamma N_P}{V}} = G_d \frac{n_T - n_t}{1 + \varepsilon_G \frac{\Gamma N_P}{V}}$$

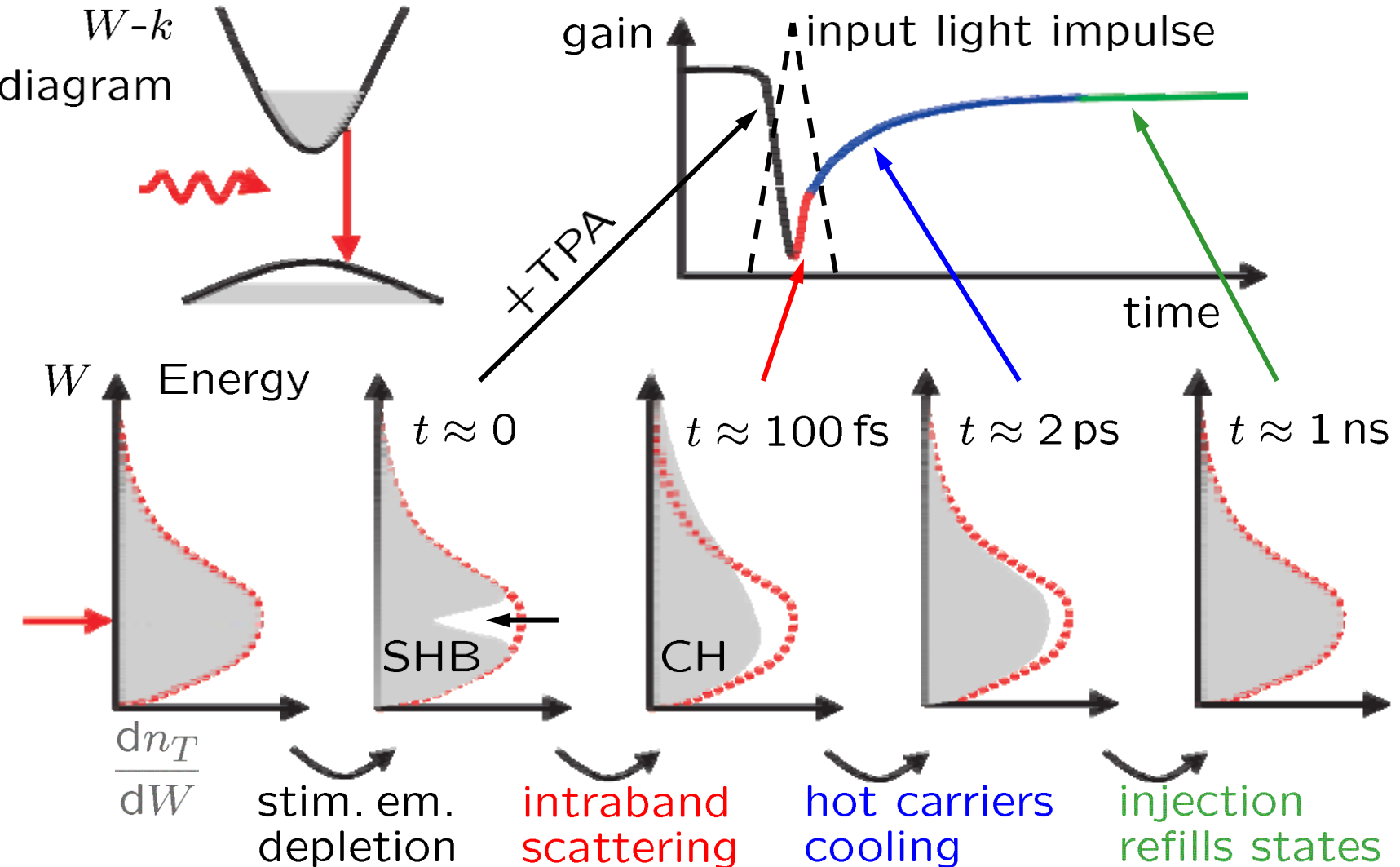


Empty VB (very high and constant  $p = n_A$ , i. e.,  $f_V \approx 0$  in range of interest, complete inversion  $n_{sp} = 1$ )  $\rightarrow$  (transp. concentration) = ( $n_t = 0$ )  $\rightarrow$  slightest  $n_T$ -concentration in CB establishes some gain. Negligible gain compression  $\varepsilon_G = 0$   $\rightarrow$  linear gain dependency:

$$G(n_T) = G_d n_T$$



# Carrier/Gain Depletion and Recovery



Modified from: Mørk, J. et al. IEEE LEOS Newsletter 16 (2002) 21–24. Fig. 2. — Mørk, J. et al. Optics & Photonics News July (2003) 42–48



# LD — Rate Equations

Rate equations heuristically, phenomena through which  $N_P$ ,  $n_TV$  change in active volume  $V$ . Longitudinally and laterally single-mode laser:

$$\underbrace{\frac{dN_P}{dt}}_{\text{change of photon number per time}} = \underbrace{+ N_P \Gamma G(n_T, N_P)}_{\text{stim. gen. photons per time}} + \underbrace{Q \frac{n_TV}{\tau_{\text{eff}}}}_{\text{spont. gen. ph. p. mode, time}} - \underbrace{\frac{N_P}{\tau_P}}_{\text{stim. depl. ph. p. time}}$$

$$\underbrace{\frac{d(n_TV)}{dt}}_{\text{change of electron number per time}} = \underbrace{- N_P \Gamma G(n_T, N_P)}_{\text{stim. depl. electrons per time}} - \underbrace{\frac{n_TV}{\tau_{\text{eff}}}}_{\text{spont. depl. electrons per time}} + \underbrace{\frac{I}{e}}_{\text{inj. electr. per time}}$$

Fraction of spontaneous recombinations leading to photons in oscillating mode is spontaneous emission factor  $Q$ :

$$Q = \frac{\Gamma r_{\text{sp}}^{(\text{eM})}}{r_{\text{eff}}} = \frac{\Gamma r_{\text{sp}}}{r_{\text{eff}}} \frac{\rho(f)}{\varrho_{\text{tot}}(f)V} = \Gamma \frac{\tau_{\text{eff}}}{\tau_{\text{sp}}} \frac{\rho(f)}{\varrho_{\text{tot}}(f)V}$$





## LD — Rate Equations. Threshold

$Q = 0$ ,  $N_P G \ll n_T V / \tau_{\text{eff}} \rightarrow$  Definition of **lasing threshold** (subscript  $S$ ) for  $d/dt = 0$ . Above threshold: Device oscillates.

$$\Gamma G(n_{TS}, 0) = \Gamma G_S = \frac{1}{\tau_P} = v_g \left( \alpha_V - \frac{\ln(R_1 R_2)}{2L} \right),$$

$$\frac{I_S}{e} = \frac{n_{TS} V}{\tau_{\text{eff}}} = r_{\text{eff}} V$$

At threshold carrier concentration  $n_T = n_{TS} \rightarrow$  net gain rate  $\Gamma G_S$  compensates loss rate  $1/\tau_P$ .  $\Gamma G_S > G(n_T, N_P) = G(n_t, N_P) = 0$ . Only above threshold:

**(photon number generated per  $t$ ) > (photon number annihilated)**

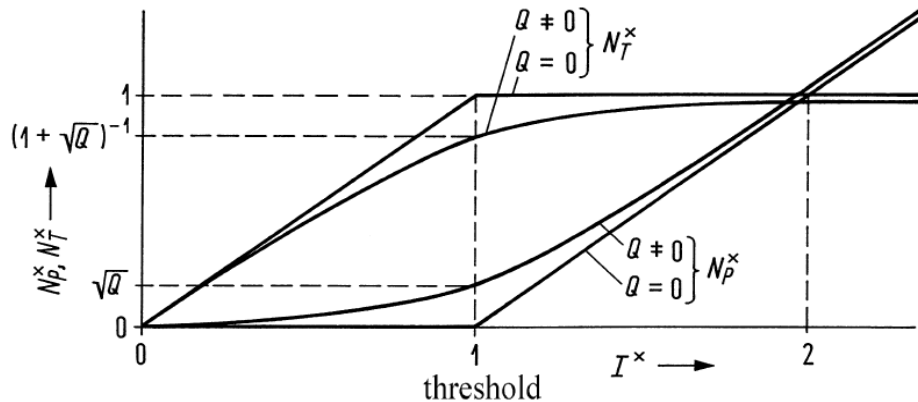
Maximum  $\tau_P$  for minimum mirror transmission losses.

**Threshold current density  $J_S = I_S/(bL)$**  for 5-layer structure minimum for optimum height  $d$  of active layer:

$$J_S = \frac{I_S}{bL} = \frac{en_t}{\tau_{\text{eff}}} \left[ d + \frac{\Gamma \alpha_V + \alpha_R}{g_0} \frac{d}{\Gamma(d)} \right], \quad \Gamma(d) = \begin{cases} d^2 & \text{for } d \text{ small} \\ 1 & \text{for } d \text{ large} \end{cases}, \quad J_S = c_1 d + \frac{c_2}{d}$$



# LD — Rate Equations. Characteristic Curves



**Fig. 3.21.** Normalized photon number  $N_P^\times$  and normalized CB carrier density  $N_T^\times$  as a function of the normalized injection current  $I^\times$ . For  $Q \neq 0$  a simplified gain dependence  $G^\times = N_T^\times$

## DC solution:

$$\begin{aligned}
 I^\times \leq 1: \quad & N_T^\times = I^\times, \quad N_P^\times = 0, \quad Q = 0, \\
 I^\times > 1: \quad & N_T^\times = 1, \quad N_P^\times = I^\times - 1, \quad G^\times = 1,
 \end{aligned}$$

## Normalized rate equations:

$$\begin{aligned}
 \tau_P \frac{dN_P^\times}{dt} &= N_P^\times (G^\times - 1) + Q N_T^\times, \\
 \tau_{\text{eff}} \frac{dN_T^\times}{dt} &= I^\times - N_T^\times - N_P^\times G^\times
 \end{aligned}$$



# LECTURE 13



# LD — Small-Signal Intensity Modulation. Fourier Solution

**Perturbation ansatz** We assume a static operation point above threshold given by the time-independent quantities  $N_{P0}$ ,  $n_{T0}$ ,  $G_0 = G(n_{T0}, N_{P0})$ ,  $\tau_P$ ,  $\tau_{\text{eff}}$ ,  $\varepsilon_G$  in Eqs. (3.83), (3.93), and small time-dependent perturbations  $N_{P1}(t)$ ,  $n_{T1}(t)$ ,  $I_1(t)$ ,

$$\begin{aligned} N_P(t) &= N_{P0} + N_{P1}(t), & G(t) &= G_0 + \frac{\partial G_0}{\partial n_{T0}} n_{T1}(t) + \frac{\partial G_0}{\partial N_{P0}} N_{P1}(t), \\ n_T(t) &= n_{T0} + n_{T1}(t), & G_0 &= G(n_{T0}, N_{P0}), & I(t) &= I_0 + I_1(t). \end{aligned} \quad (3.103)$$

The differential gain rate  $\partial G_0/\partial n_{T0}$  has typical values of  $1.8 \times 10^{-6} \dots 2.9 \times 10^{-6} \text{ cm}^3 \text{ s}^{-1}$ . Substituting Eq. (3.103) into Eq. (3.83) and neglecting products of perturbation quantities, we solve the linearized rate equations with a Fourier ansatz  $X_1(t) = X_1(\omega) \exp(j\omega t)$ , where  $X_1(\omega)$  is the complex amplitude at the modulation frequency  $f = \omega/(2\pi)$ ,

$$\begin{aligned} N_{P1}(\omega) \left( j\omega + \frac{1}{\tau_P} - \frac{\Gamma G_0}{1 + \varepsilon_G \frac{\Gamma N_{P0}}{V}} \right) &= \left( \frac{Q}{\tau_{\text{eff}}} + \frac{N_{P0}}{V} \frac{\partial \Gamma G_0}{\partial n_{T0}} \right) n_{T1}(\omega) V, \\ n_{T1}(\omega) V \left( j\omega + \frac{1}{\tau_{\text{eff}}} + \frac{N_{P0}}{V} \frac{\partial \Gamma G_0}{\partial n_{T0}} \right) &= \frac{I_1(\omega)}{e} - \frac{\Gamma G_0}{1 + \varepsilon_G \frac{\Gamma N_{P0}}{V}} N_{P1}(\omega). \end{aligned} \quad (3.104)$$

Elimination of  $n_{T1}(\omega)$  leads to the modulation transfer function

$$\frac{N_{P1}(\omega)}{I_1(\omega)} = \underbrace{\left( \frac{N_{P0}}{V} \frac{\partial \Gamma G_0}{\partial n_{T0}} + \frac{Q}{\tau_{\text{eff}}} \right)}_{\approx 1} \frac{\omega_r^2}{(j\omega)^2 + 2\gamma_r(j\omega) + \omega_r^2} \quad (3.105)$$



## LD — Small-Signal Intensity Modulation

Static operation point above threshold at  $N_{P0}$ ,  $n_{T0}$ ,  $\tau_P$ ,  $\tau_{\text{eff}}$ ,  $G_0 = G(n_{T0}, N_{P0})$ ,  $\varepsilon_G$ . Small perturbations  $N_{P1}(t)$ ,  $n_{T1}(t)$ ,  $I_1(t)$ :

$$N_P(t) = N_{P0} + N_{P1}(t), \quad G(t) = G_0 + \frac{\partial G_0}{\partial n_{T0}} n_{T1}(t) + \frac{\partial G_0}{\partial N_{P0}} N_{P1}(t),$$

$$n_T(t) = n_{T0} + n_{T1}(t), \quad G_0 = G(n_{T0}, N_{P0}), \quad I(t) = I_0 + I_1(t)$$

Elimination of  $n_{T1}(\omega)$  leads to modulation transfer function:

$$\frac{N_{P1}(\omega)}{I_1(\omega)} \approx \frac{\omega_r^2}{(j\omega)^2 + 2\gamma_r(j\omega) + \omega_r^2}$$

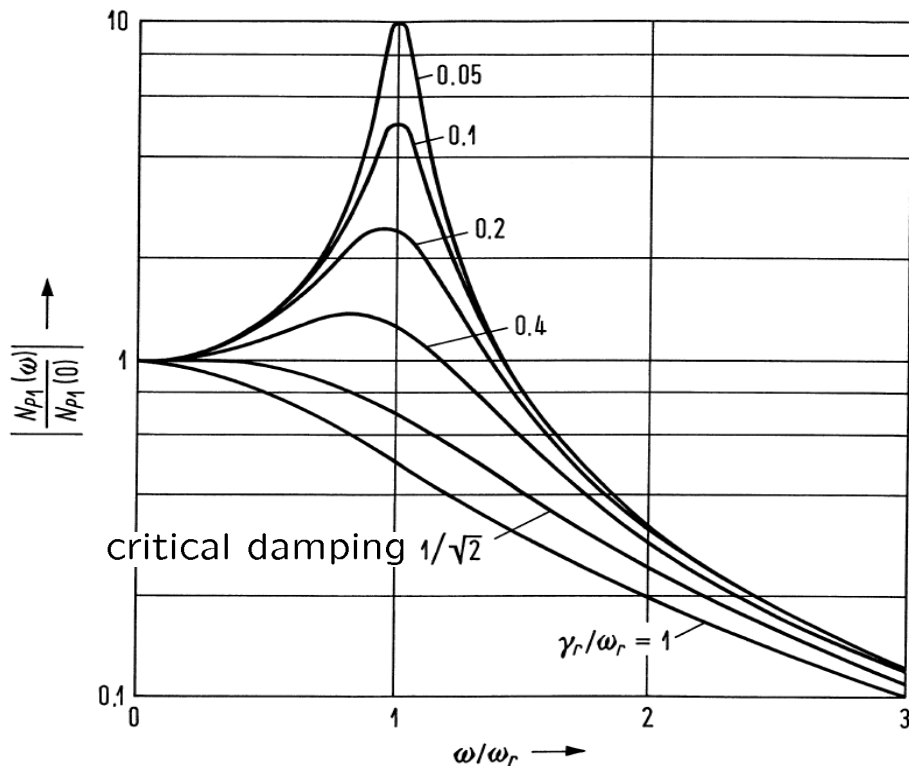
Angular relaxation frequency  $\omega_r$ , damping constant  $\gamma_r$ :

$$\omega_r^2 \tau_P \approx \frac{N_{P0}}{V} \frac{\partial \Gamma G_0}{\partial n_{T0}}, \quad \approx \tau_P^{-1} \varepsilon_G \Gamma N_{P0} / V$$

$$2\gamma_r \approx \frac{1}{\tau_{\text{eff}}} + \underbrace{\frac{N_{P0}}{V} \frac{\partial \Gamma G_0}{\partial n_{T0}} + \Gamma G_0 \varepsilon_G \frac{\Gamma N_{P0}}{V}}_{= \omega_r^2 K_r}$$



# LD — Small-Signal Intensity Modulation. Transfer Function



$$\left| \frac{N_{P1}(\omega)/\tau_P}{I_1/e} \right| \rightarrow \max :$$

$$\omega_R = \sqrt{\omega_r^2 - 2\gamma_r^2}$$

$$\left| \frac{N_{P1}(\omega_{3\text{dB}})}{N_{P1}(0)} \right| = \frac{1}{\sqrt{2}},$$

$$\omega_{3\text{dB}}^2 = (\omega_r^2 - 2\gamma_r^2)$$

$$+ \sqrt{(\omega_r^2 - 2\gamma_r^2)^2 + \omega_r^4}$$



**Fig. 3.22.** Modulus of current-light modulation transfer function as a function of normalized current modulation frequency for various values of  $\gamma_r/\omega_r$

$$\omega_r^2 \tau_P \approx \frac{N_{P0}}{V} \frac{\partial(\Gamma G_0)}{\partial n_{T0}}, \quad \omega_{3\text{dB}}^{\max} = \omega_r = \gamma_r \sqrt{2}, \quad \gamma_r \sqrt{2} \approx \frac{1}{2} \omega_r^2 K_r \sqrt{2},$$

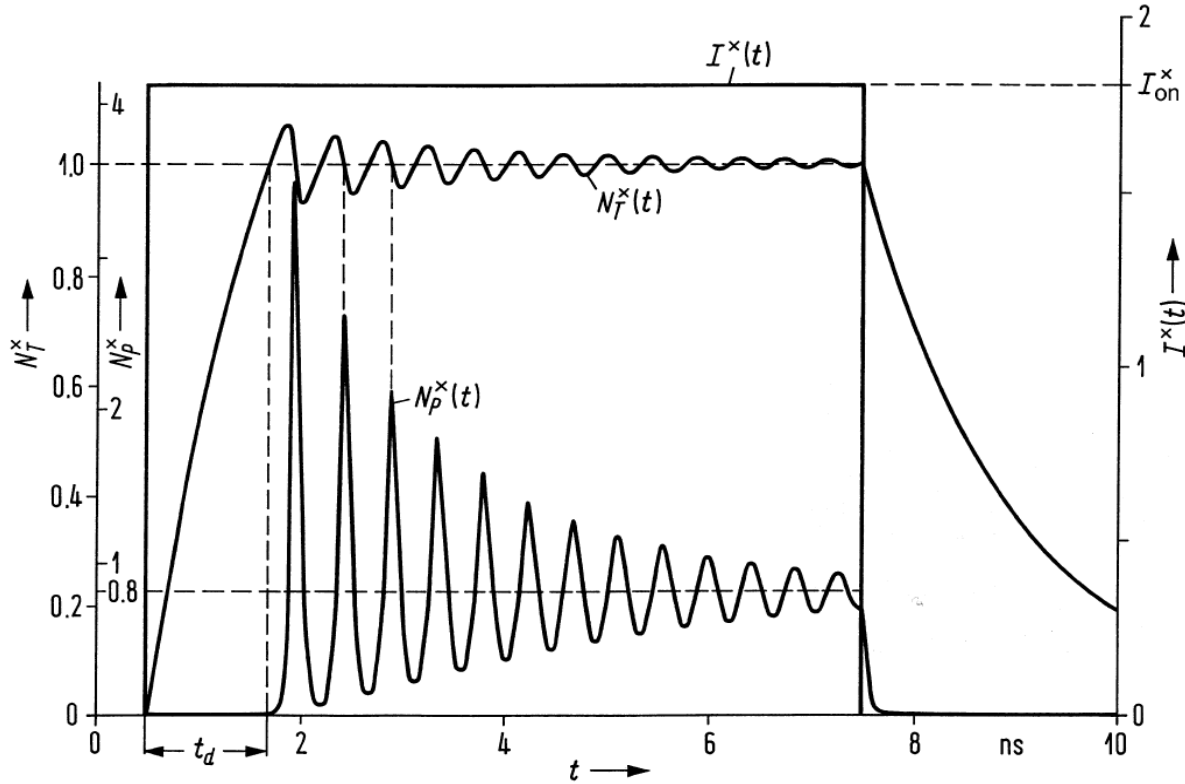
$$2\gamma_r \approx \frac{1}{\tau_{\text{eff}}} + \omega_r^2 K_r \quad \omega_{3\text{dB}}^{\max} = \frac{\sqrt{2}}{K_r},$$

$$K_r = \tau_P + \frac{\epsilon G}{\partial G_0 / \partial n_{T0}}$$





# LD — Large-Signal Intensity Modulation



**Fig. 3.24.** Relaxation oscillation for a current step  $I^\times = 1.8$ . Parameters are  $\tau_P = 2.5$  ps,  $\tau_{\text{eff}} = 1.5$  ns,  $Q = 5 \times 10^{-4}$

Normalized rate equations:

$$\tau_P \frac{dN_P^\times}{dt} = N_P^\times (G^\times - 1) + Q N_T^\times, \quad \tau_{\text{eff}} \frac{dN_T^\times}{dt} = I^\times - N_T^\times - N_P^\times G^\times$$



# LD — Amplitude-Phase Coupling. Line Broadening

Dependencies of gain rate  $G(f, n_T)$ , modal power gain  $g$  and  $-n_i$  because of emission spectrum and via quasi Fermi levels.  $n(f, n_T)$  because of **band filling**, **Coulomb interact.**, **free-carrier absorpt.** ◀

At LD oscillation frequency  $\rightarrow \Delta n < 0$  and (via Kramers-Kronig)  $\Delta g > 0$  for  $\Delta n_T > 0$ . Line broadening factor, Henry factor,  $\alpha$ -factor: ◀

$$\alpha = \frac{\partial n / \partial n_T}{\partial n_i / \partial n_T} = -2k_0 \frac{\partial n / \partial n_T}{\partial(\Gamma g - \alpha_V) / \partial n_T} \approx -2k_0 \frac{\partial n / \partial n_T}{\partial(\Gamma g) / \partial n_T} > 0$$

For LD oscillator:  $\alpha = 2 \dots 8$ . Correlation between amplitude and phase. Spontaneous emissions  $\rightarrow$  amplitude and phase changes. Amplitude change  $\rightarrow$  secondary phase change  $\rightarrow$  broadening of the emission line (inversion factor  $n_{sp}$ ): ◀

$$\Delta f_H P_a = \text{const} \cdot n_{sp} (1 + \alpha^2) h f v_g^2 (\alpha_V + \alpha_R) \alpha_R, \quad n_{sp} = \frac{N_2}{N_2 - N_1}$$



## LD — Amplitude-Phase Coupling. Chirp

Stationary laser oscillation, operating point (subscript 0) at  $G(n_{T0}) = 1/\tau_P$ ,  $G^{\times} = \Gamma G(n_{T0}, N_{P0}) \tau_P = 1$ . Angular optical frequency  $\omega_0$ . Changing  $n_T$  differentially,  $dn_T \rightarrow$  gain rate  $dG$ , and “instantaneous” (slowly varying on  $(1/f_0)$ -scale) optical frequency  $\omega$  deviating by  $d\omega$ . Frequency difference  $\Delta\omega$  defines time derivative of optical phase,  $d\varphi/dt = \Delta\omega$ ,  $\omega n \cdot 2L/c = m_z \cdot 2\pi$ : ◀

$$d(\omega n(\omega)) = \frac{\partial(\omega n)}{\partial \omega} d\omega + \frac{\partial(\omega n)}{\partial n} dn = \left( \overbrace{n + \omega \frac{\partial n}{\partial \omega}}^{n_g} \right) d\omega + \omega dn \stackrel{!}{=} 0,$$

$$d\omega = -\frac{\omega}{n_g} dn = -\frac{\omega}{n_g} \frac{\partial n}{\partial n_T} dn_T = \frac{\alpha \omega}{2k_0 n_g} \frac{\partial(\Gamma g)}{\partial n_T} dn_T$$
◀

$$\approx \Delta\omega = \omega - \omega_0 = \underbrace{\frac{d\varphi}{dt}}_{=0} = \frac{\alpha}{2} v_g \frac{\partial(\Gamma g)}{\partial n_T} \Delta n_T \approx \frac{\alpha}{2} \frac{\partial(\Gamma G)}{\partial n_T} \Delta n_T$$

$$\frac{d\varphi}{dt} = \frac{\alpha}{2} \left( \underbrace{\frac{\partial(\Gamma G)}{\partial n_T} \Delta n_T + \Gamma G(n_{T0})}_{\Gamma G(n_T)} - \frac{1}{\tau_P} \right) = \frac{\alpha}{2} \left( \Gamma G - \frac{1}{\tau_P} \right) \approx \frac{\alpha}{2} \frac{1}{N_P} \frac{dN_P}{dt}$$



# LD — Amplitude-Phase Coupling. Electric Field

$$\frac{d\varphi}{dt} = \frac{\alpha}{2} \left( \underbrace{\frac{\partial(\Gamma G)}{\partial n_T} \Delta n_T + \overbrace{\Gamma G(n_{T0})}^{=0}}_{\Gamma G(n_T)} - \frac{1}{\tau_P} \right) = \frac{\alpha}{2} \left( \Gamma G - \frac{1}{\tau_P} \right) \approx \frac{\alpha}{2} \frac{1}{N_P} \frac{dN_P}{dt}$$

Rate equations with optical phase change supplement, including spontaneous emission into oscillating mode ( $Q \neq 0 \rightarrow \Gamma G < 1/\tau_P$ ):

$$\frac{dN_P}{dt} = N_P \left( \Gamma G - \frac{1}{\tau_P} \right) + Q \frac{n_T V}{\tau_{\text{eff}}},$$

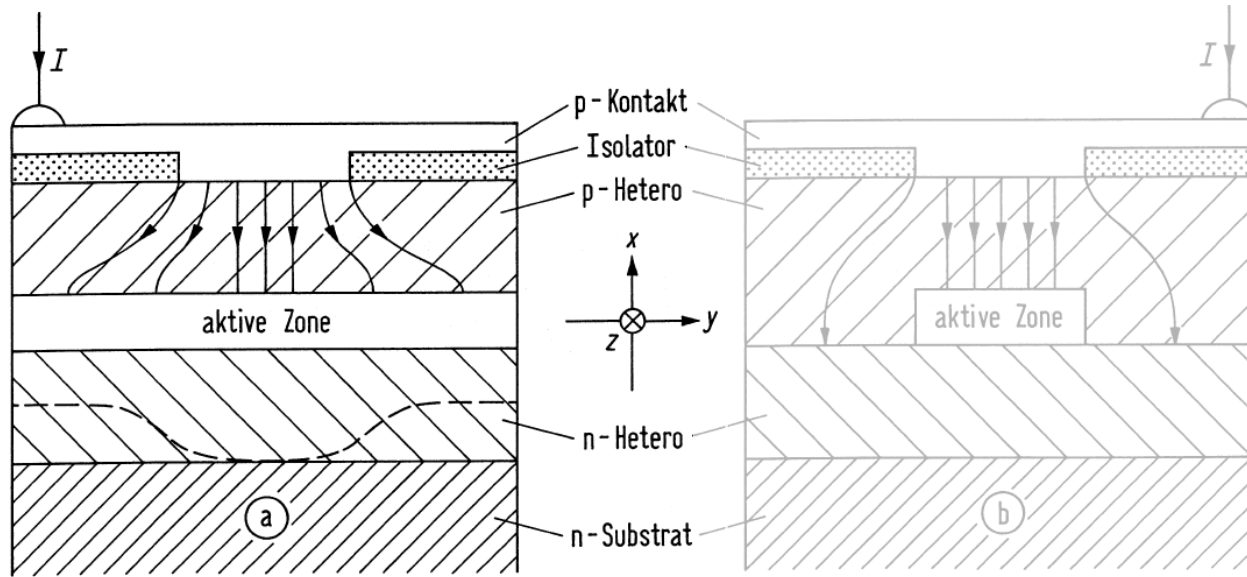
$$\frac{d\varphi}{dt} = \frac{\alpha}{2} \left( \Gamma G - \frac{1}{\tau_P} \right),$$

$$\underline{E}(t) \sim \sqrt{N_P(t)} \exp\{j[\omega_0 t + \varphi(t)]\},$$

$$\frac{d(n_T V)}{dt} = -N_P \Gamma G - \frac{n_T V}{\tau_{\text{eff}}} + \frac{I}{e}$$



# LD — Device Structures with Gain and Index Guiding



Basic laser diode structures. (a) Gain-guided laser (b) Index-guided laser. The origin of the coordinate system is located in the centre of the active zones (p-Kontakt = p-contact, Isolator = insulator, aktive Zone = active zone).

**Gain guiding:** Current confined

$$\rightarrow g - \alpha_V = -2k_0 n_i$$

**Effective  $n$**  in high-current region lower  $\rightarrow$  antiguiding

**Lateral decrease of  $n_i$**  dominates.

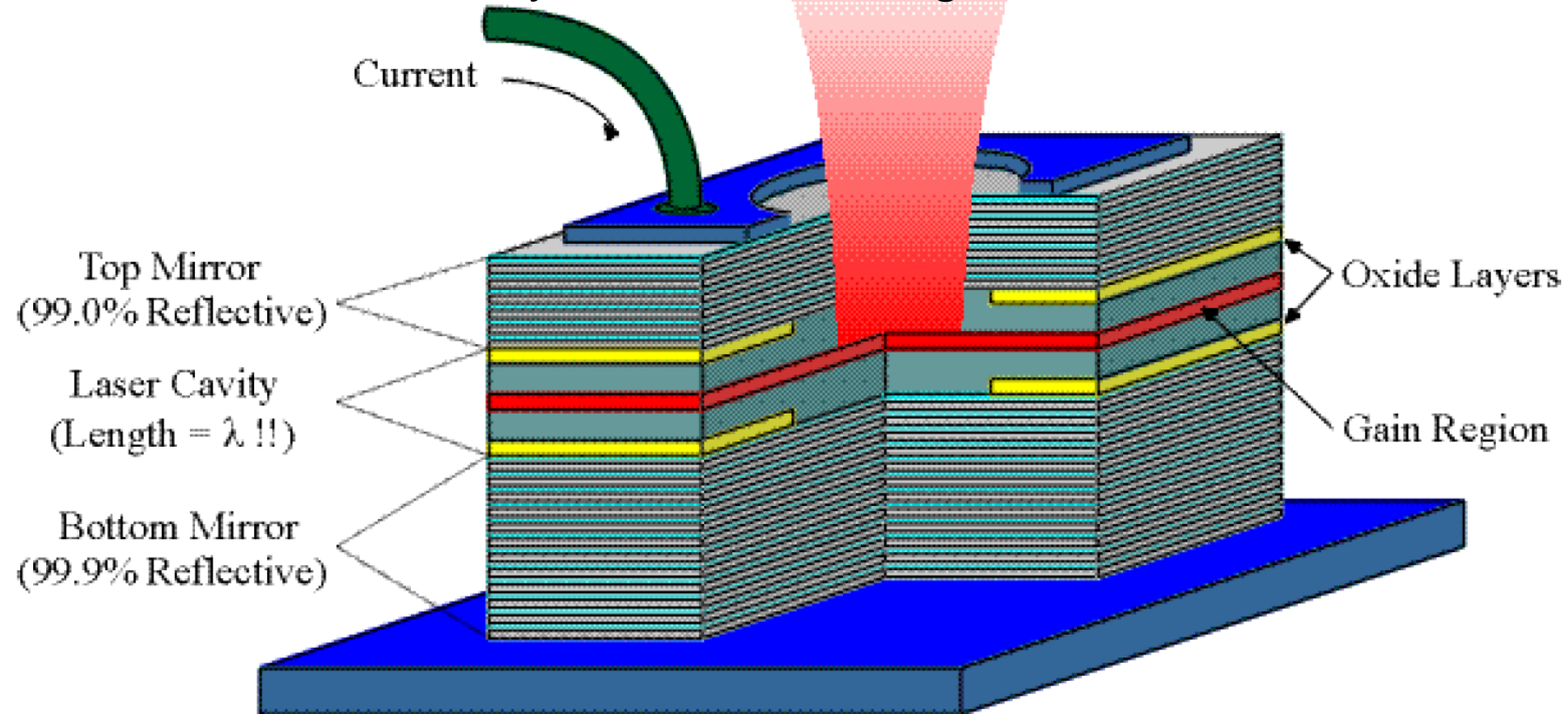
**High threshold  $I_S = 100 \text{ mA}$**

**Index guiding:** Strip waveguide cavity by lateral heterojunctions.

**Low threshold  $I_S = 10 \text{ mA}$**



# Vertical Cavity Surface Emitting Laser — VCSEL



**VCSEL operates in single longitudinal mode:** Extremely small cavity length  $L = \lambda_e/2 \approx 1 \mu\text{m}$  so that  $q = 1$ .

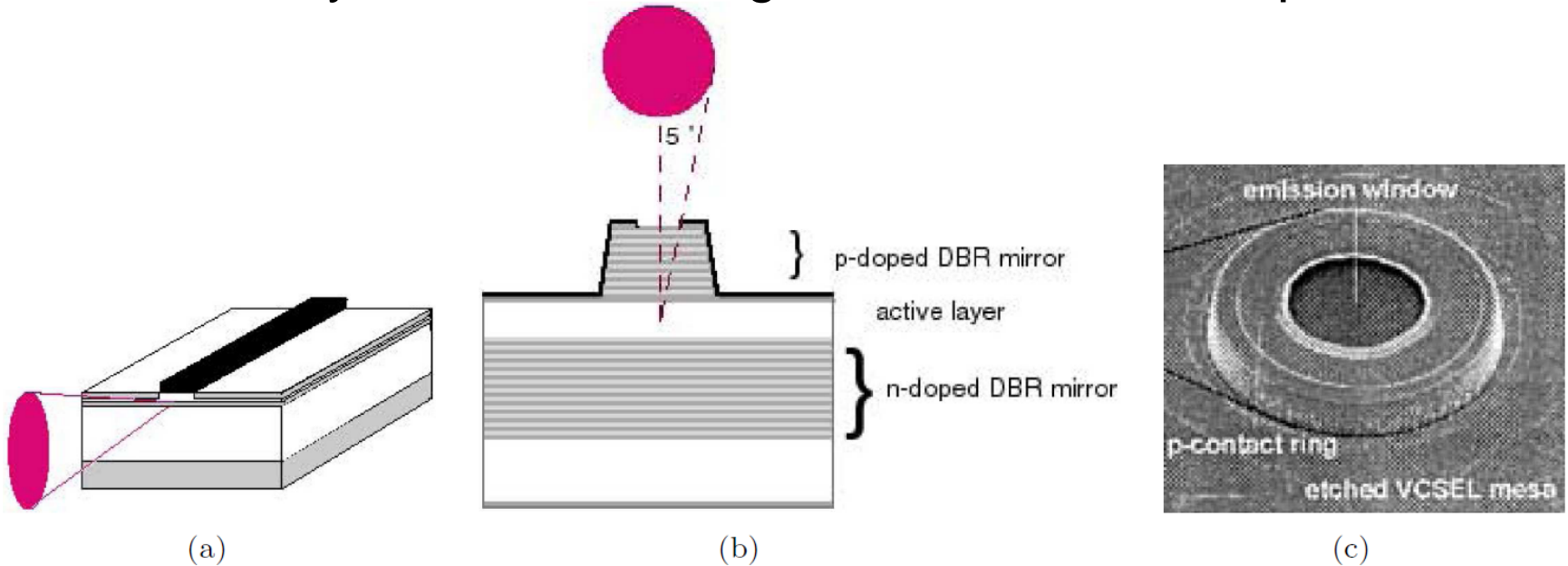
**Mode spacing**  $\Delta f_z = c/(n_g \lambda_e) = c/\lambda \approx 300 \text{ THz}$  for  $\lambda = 1 \mu\text{m}$  exceeds gain bandwidth  $\Delta f_H \approx 12 \text{ THz}$  by far.

<http://www.ino.it/~gianni> Giovanni Giacomelli: Progetto INOA 4.2 : strutture spazio-temporali in laser a cavità verticale  
Spatio-temporal structures in vertical cavity lasers. F:\U\Wofreu\PCTEX\SKRIPTEN\Giacomelli\INO\_Gianni Giacomelli.pdf





# Vertical Cavity Surface Emitting Laser — Beam Shape and SEM



Edge-emitting and vertically-emitting laser diodes (a) edge-emitting laser diode and far-field radiation characteristic (b) VCSEL layer structure. p-doped DBR mirror: 25 layers  $\text{Al}_{0.3}\text{Ga}_{0.7}\text{As}/\text{AlAs}$ ; active zone: 220 nm  $\text{Al}_{0.3}\text{Ga}_{0.7}\text{As}$  with 3  $\text{Al}_{0.12}\text{Ga}_{0.88}\text{As}$  quantum films, height about 7 nm each; n-doped DBR mirror: 40 layers  $\text{Al}_{0.3}\text{Ga}_{0.7}\text{As}/\text{AlAs}$  (c) microscopic image of VCSEL (all after reference Footnote 49 on Page 122)

**Lower resonator mirror:** 40 alternating layers of  $\text{Al}_x\text{Ga}_{1-x}\text{As}$  and  $\text{AlAs}$ , each layer  $\lambda_e/4$  thick, power reflection factor  $R_1 \geq 99.99\%$

**Output top mirror:** 25  $\lambda_e/4$  layers, reflectivity  $R_2 = 99.9\%$

**High resonator efficiency, small gain medium volume**  $\rightarrow I_{\text{th}} \sim \text{mA}$



# LECTURE 14



# Semiconductor Optical Amplifier (SOA) Gain

Gain relations of Fabry-Perot laser:

$$\exp(-j\bar{k}z), \quad \left\{ \begin{array}{l} \bar{k} = k_0 \bar{n} = k + \frac{1}{2}j(g - \alpha_V), \\ \bar{n} = n - jn_i, \\ k_0 = \omega/c, \end{array} \right\}, \quad g - \alpha_V = -2k_0 n_i$$

$$G - \frac{1}{\tau_P} = \frac{1}{N_P} \frac{dN_P}{dt}, \quad \frac{N_P(\tau_U)}{N_P(0)} = \exp\left[\left(G - \frac{1}{\tau_P}\right)\tau_U\right], \quad \tau_U = \frac{2L}{v_g}$$

$$\exp\left[\left(G - 1/\tau_P\right)\tau_U\right] = R_1 R_2 \exp\left[(g - \alpha_V)2L\right]$$

SOA with distributed single-pass gain  $\mathcal{G}_s$ :

$$\mathcal{G}_s = \exp[(\Gamma g - \alpha_{Ve})L], \quad \varphi = \beta L = k_0 n_e L$$

Residual mirror reflectivities  $R_{1,2} \neq 0 \rightarrow$  FP amplification factor  $\mathcal{G}$ :

$$\mathcal{G} = \frac{\mathcal{G}_s(1 - R_1)(1 - R_2)}{(1 - \mathcal{G}_s\sqrt{R_1 R_2})^2 + 4\mathcal{G}_s\sqrt{R_1 R_2} \sin^2 \varphi},$$

$$\varphi = \beta L, \quad \text{resonances: } \varphi_z = \omega_z n_e L / c = m_z \pi, \quad m_z = 1, 2, 3, \dots$$



# SOA Single-Pass Gain and Ripple

FP amplification factor  $\mathcal{G}$ :

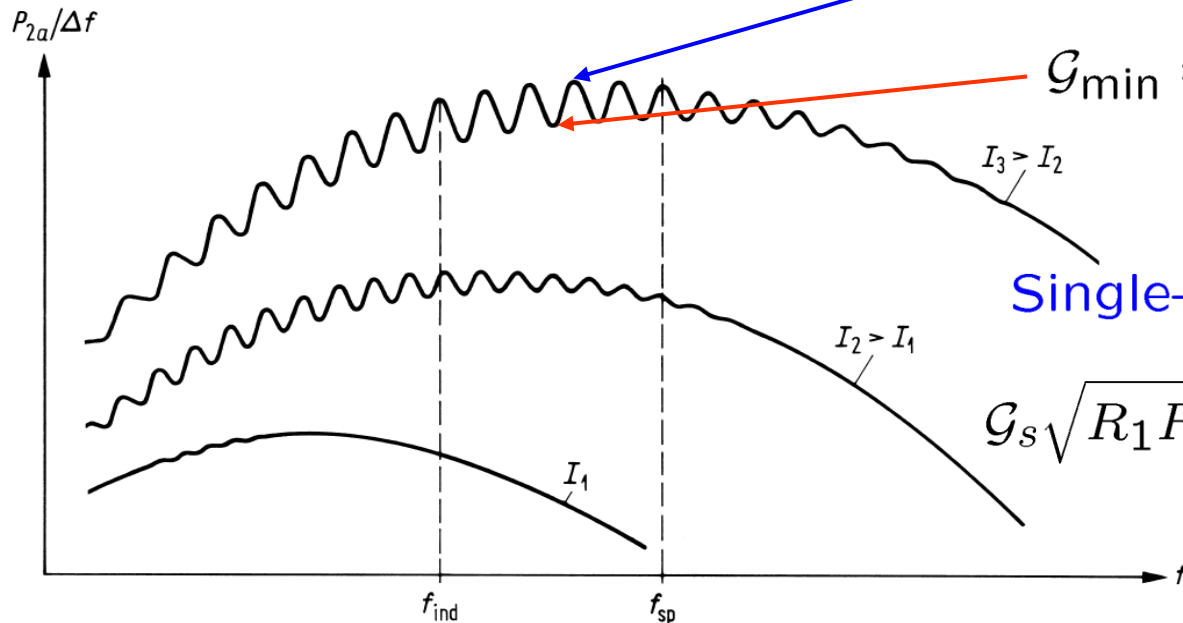
$$\mathcal{G} = \frac{\mathcal{G}_s(1 - R_1)(1 - R_2)}{(1 - \mathcal{G}_s\sqrt{R_1R_2})^2 + 4\mathcal{G}_s\sqrt{R_1R_2} \sin^2 \varphi},$$

$$\varphi = \beta L, \quad \text{res.: } \varphi_z = \omega_z n_e L / c = m_z \pi.$$

Res. & anti-res.:

$$\mathcal{G}_{\max} = \frac{\mathcal{G}_s(1 - R_1)(1 - R_2)}{(1 - \mathcal{G}_s\sqrt{R_1R_2})^2},$$

$$\mathcal{G}_{\min} = \frac{\mathcal{G}_s(1 - R_1)(1 - R_2)}{(1 + \mathcal{G}_s\sqrt{R_1R_2})^2}$$



Single-pass gain from ripple:

$$\mathcal{G}_s\sqrt{R_1R_2} = \frac{\sqrt{\mathcal{G}_{\max}/\mathcal{G}_{\min}} - 1}{\sqrt{\mathcal{G}_{\max}/\mathcal{G}_{\min}} + 1}$$

$$\mathcal{G}_{\max}/\mathcal{G}_{\min} = 2:$$

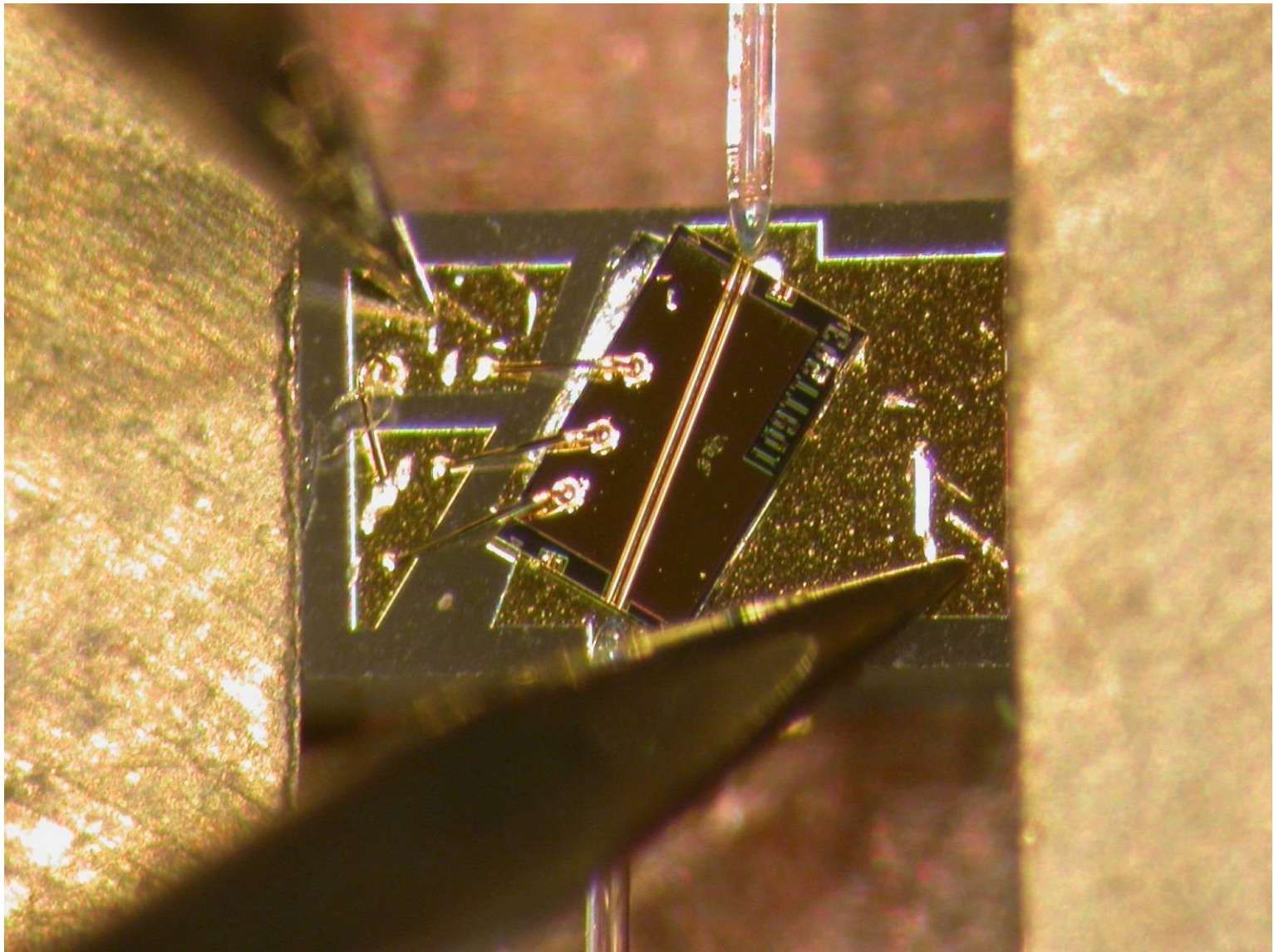
$$\mathcal{G}_s\sqrt{R_1R_2} = 0.17$$

Conv. FP:  $|\text{---}|$ . Angled:  $|\text{ / }| \rightarrow R_{\text{eff} 1,2} \approx 10^{-4}$

Near-travelling-wave amplifier. Schematic of the spectral output power density  $P_{2a}/\Delta F$  of amplified spontaneous emission as transmitted through mirror  $R_2$  for varying injection currents  $I_1 < I_2 < I_3$ . The frequencies of maximum gain and maximum spontaneous emission are denoted as  $f_{\text{ind}}$  and  $f_{\text{sp}}$  for an operating current  $I = I_3$ .

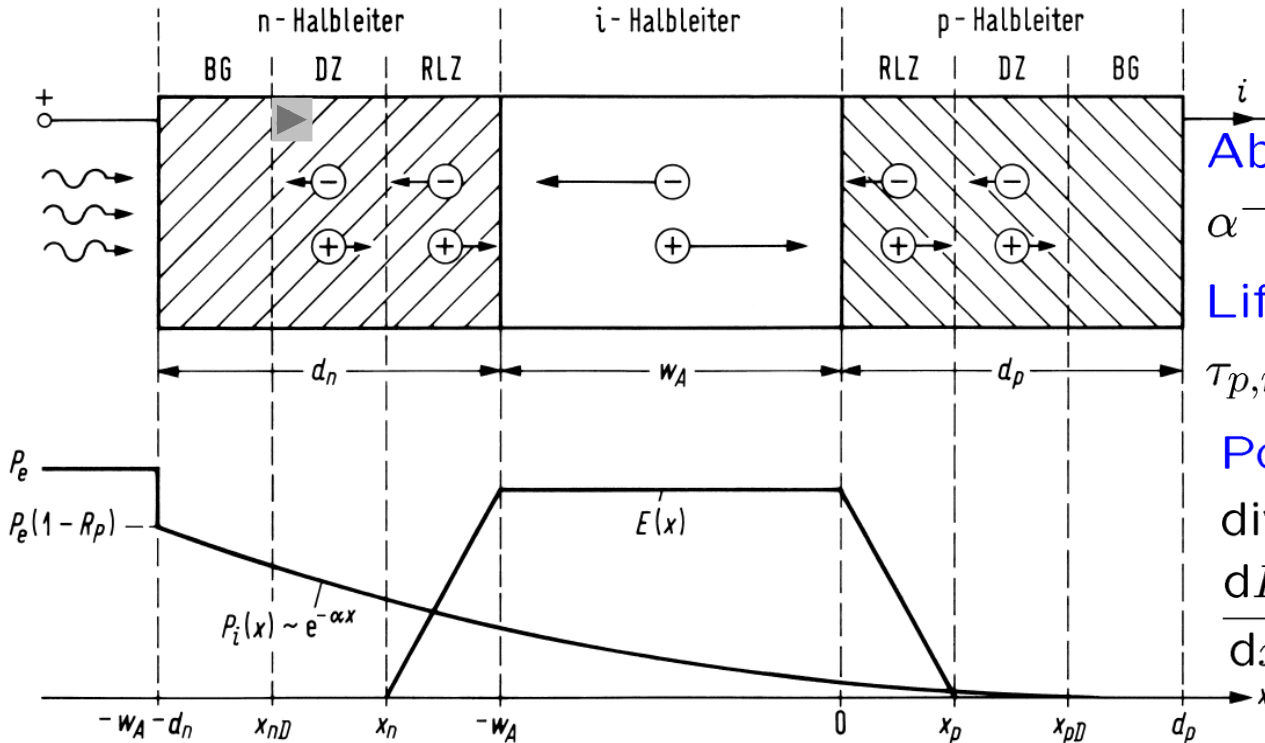
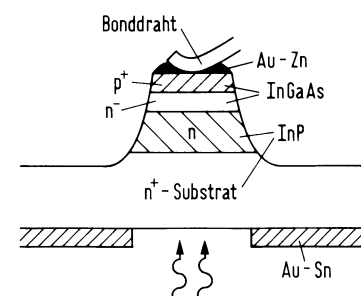
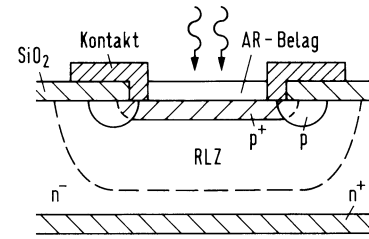


# SOA Chip with Angled Facets and Lensed Fibres





# Pin Photodiode



Absorption length:  
 $\alpha^{-1} = 1 \dots 10 \dots 20 \mu\text{m}$

Lifetime:  
 $\tau_{p,n} = L_{p,n}^2 / D_{p,n}$

Poisson equation:  
 $\text{div}(\epsilon_0 \epsilon_r \vec{E}) = \rho$   
 $\frac{dE}{dx} = \pm \frac{en_{D,A}}{\epsilon_0 \epsilon_r}$

Schematic of a pin-diode. BG contact region (= *Bahngebiet*), DZ diffusion zone, RLZ space-charge (or depletion) region (= *Raumladungszone*).  $P_e$  light power incident from region external of semiconductor,  $R_P$  power reflection factor of the semiconductor surface,  $P_i(x)$  light power inside the semiconductor,  $\alpha$  light power attenuation constant,  $d_n$  ( $d_p$ ) length of n-doped (p-doped) semiconductor,  $w_A$  length of intrinsic absorption zone,  $E(x)$   $x$ -component of electric field. Halbleiter = semiconductor





# Sensitivity of a pin-Photodetector

We compute the sensitivity  $S$  (responsivity) of a pin-photodiode, which we describe by

- its technological structure, by
- a reduction to an easy-to-handle model, and by
- appropriate basic equations.

Continuity and transport equations are written

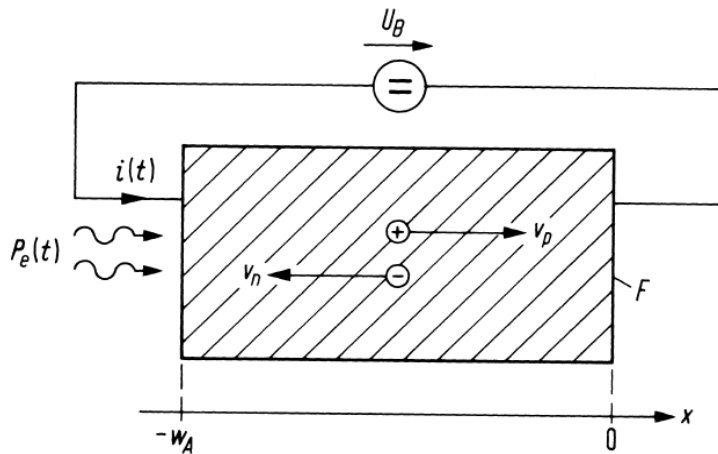
- in one-dimensional form, specified with
- quantum efficiency and generation rate, and finally
- solved for the DC case.

We find that for an external optical power  $P_e$  (photon energy  $hf_e$ )

- each absorbed photon generates one  $e-h$  pair (prob.  $\eta$ ), which
- transports one elementary charge  $e$  in the external circuit, so
- the rate of generated charges  $i/e$  (photocurrent  $i$ ) equals
- the photon absorption rate  $\eta P_e / (hf_e)$  resulting in
- the sensitivity  $S = \frac{\eta e}{hf_e}$  and a photocurrent  $i = SP_e$ .



# Absorption Zone — Short-Circuit Current



Transport equations ( $\vec{v}_n$ ,  $\vec{v}_p$  drift velocity;  $D_n$ ,  $D_p$  diffusion constant;  $\mu_n$ ,  $\mu_p$  mobility,  $\vec{E}$  electric field):

$$\vec{J}_p = ep\vec{v}_p - eD_p \text{grad } p,$$

$$\vec{J}_n = -en_T\vec{v}_n + eD_n \text{grad } n_T$$

i-layer of a pin-photodiode (one-dimensional case, cross-section area  $F$ ). Saturation drift velocities  $v_n > 0$  and  $v_p > 0$  for electrons and holes, incident external optical power  $P_e(t)$ , total conduction current  $i(t)$ , open-circuit voltage  $U_B$  of a battery with an internal resistance of zero



# Absorption Zone — Basic 1D-Equations

Saturation velocities  $v_n, v_p$ . Recombination rates  $r_n, r_p$  neglected (carrier lifetime much larger than drift time in absorption zone  $-w_A \leq x \leq 0$ ), diffusion currents neglected compared to field currents. Photo generation dominates,  $g_p = g_n = g$ . Currents  $i$  instead of current densities  $J$  (cross-section area  $F$ ):

$$\frac{1}{v_p} \frac{\partial i_p}{\partial t} + \frac{\partial i_p}{\partial x} = eFg, \quad i_p = Fepv_p,$$

$$\frac{1}{v_n} \frac{\partial i_n}{\partial t} - \frac{\partial i_n}{\partial x} = eFg, \quad i_n = Fen_Tv_n,$$



$$\epsilon \frac{\partial E}{\partial x} = e(p - n_T),$$

$$F\epsilon \frac{\partial}{\partial t} \left( \frac{\partial E}{\partial x} \right) = Fe \left( \frac{1}{Fev_p} \frac{\partial i_p}{\partial t} - \frac{1}{Fev_n} \frac{\partial i_n}{\partial t} \right), \quad \frac{\partial}{\partial x} \left( \underbrace{i_n + i_p + F\epsilon \frac{\partial E}{\partial t}}_{\text{total current } i(t)} \right) = 0$$



# Absorption Zone — Convection Current and External Current

Total time-dependent conduction current:

$$i(t) = i_n(x, t) + i_p(x, t) + F\epsilon \frac{\partial E(x, t)}{\partial t}$$

Averaging over absorption zone  $-w_A \leq x \leq 0$ , observe:

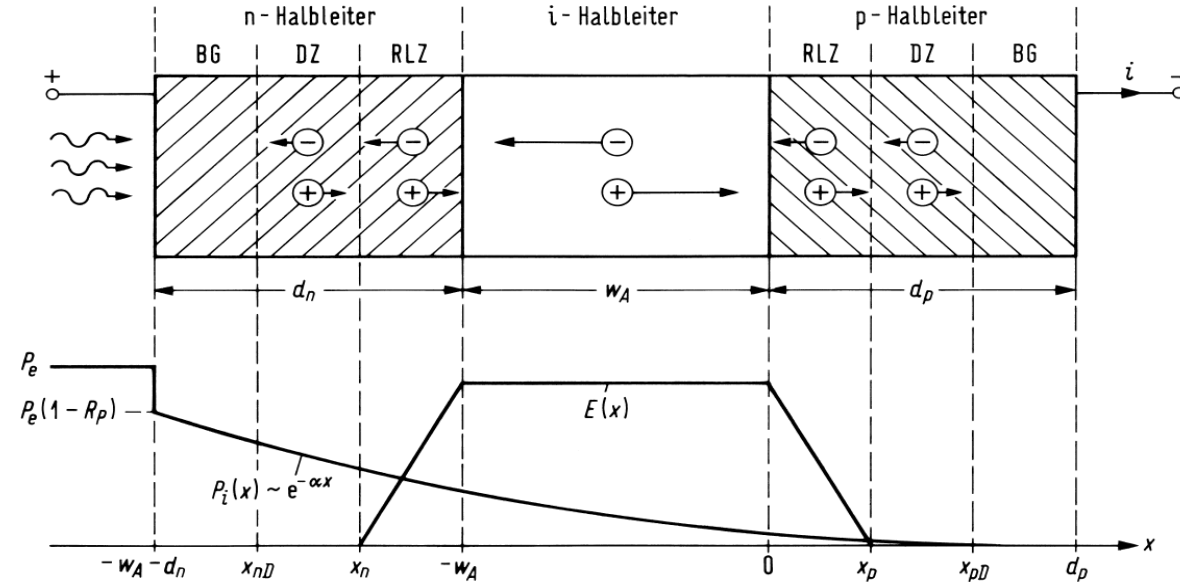
$$\int_{-w_A}^0 E(x, t) dx = U_B \quad \rightarrow \quad \int_{-w_A}^0 \frac{\partial E(x, t)}{\partial t} dx = \frac{dU_B}{dt} = 0$$

Total conduction current found (= external short-circuit current,  $dU_B = 0$ ) by averaging the sum of carrier convection currents inside absorption region  $-w_A \leq x \leq 0$ :

$$i(t) = \frac{1}{w_A} \int_{-w_A}^0 [i_n(x, t) + i_p(x, t)] dx$$



# Absorption Zone — Quantum Efficiency



If  $\alpha d_n \rightarrow 0$  (n-SC small comp. to abs. length), then  $P_i(x, t)$  in i-region:

$$P_i(x, t) = P_e(t) (1 - R_P) e^{-\alpha(x+w_A)}$$

Light transit time neglected.  $P_e$ ,  $P_i$  are powers averaged over a few optical periods. Fraction of power absorbed in i-zone is **quantum efficiency**  $\eta$ :

$$\eta = \frac{P_i(-w_A, t) - P_i(0, t)}{P_e(t)} = (1 - R_P) (1 - e^{-\alpha w_A})$$



# Absorption Zone — Generation Rate $g$ (unit $\text{cm}^{-3} \text{s}^{-1}$ )

No current harmonics produced by detection process:

$$i \sim \langle |E|^2 \cos^2(\omega_L t) \rangle = \frac{1}{2} |E|^2 \langle 1 + \cancel{\cos(2\omega_L t)} \rangle = \frac{1}{2} |E|^2$$

Absorption detectors of this kind are **unable** to emit optical photons  $2hf_L$ !

$N_P$  photons, power  $P$ :  $N_P hf_L = P \times 1 \text{ s}$

$$P_i(x, t) = P_e(t) (1 - R_P) e^{-\alpha(x+w_A)}$$

$$\left( \overline{\text{CP generation rate } g} \right) = \left( \overline{\text{photon absorption rate}} \right)$$



Power gained in  $\partial x$ :

$$\frac{\partial P_i(x, t)}{\partial x} = \frac{P_i(x + \partial x, t) - P_i(x, t)}{\partial x} = \frac{(\text{power lost or abs. in } dx) / (hf_L)}{(\text{differential volume})}$$

Power lost in  $\partial x$ :

$$\frac{-\partial P_i(x, t)}{\partial x} = \frac{P_i(x, t) - P_i(x + \partial x, t)}{\partial x} \quad g(x, t) = \frac{-\partial P_i(x, t) / (hf_L)}{F \partial x} = \frac{\alpha P_i(x, t)}{F hf_L}$$





# Absorption Zone — External Short-Circuit Current

Quantum efficiency, power decay, and generation rate:

$$P_i(x, t) = P_e(t) (1 - R_P) e^{-\alpha(x+w_A)}$$
$$g(x, t) = \frac{\alpha P_i(x, t)}{F h f_L} = \frac{\alpha P_e(t)}{F h f_L} (1 - R_P) e^{-\alpha(x+w_A)}$$
$$\eta = (1 - R_P) \left(1 - e^{-\alpha w_A}\right)$$
$$e F g(x, t) = \frac{\eta e}{h f_L} P_e(t) \frac{\alpha e^{-\alpha(x+w_A)}}{1 - e^{-\alpha w_A}}$$

A system of differential equations follows:

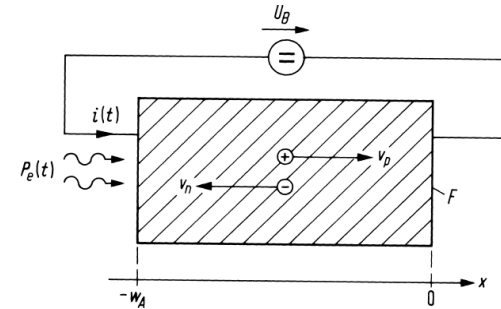
$$\frac{1}{v_p} \frac{\partial i_p(x, t)}{\partial t} + \frac{\partial i_p(x, t)}{\partial x} = e F g(x, t), \quad i_p(x, t) = F e p(x, t) v_p,$$
$$\frac{1}{v_n} \frac{\partial i_n(x, t)}{\partial t} - \frac{\partial i_n(x, t)}{\partial x} = e F g(x, t), \quad i_n(x, t) = F e n_T(x, t) v_n,$$
$$i(t) = \frac{1}{w_A} \int_{-w_A}^0 [i_n(x, t) + i_p(x, t)] dx$$



# nip-Diode — External Short-Circuit Current — Static Case

Generation rate,  $\partial/\partial t = 0$ :

$$eFg(x) = \frac{\eta e}{hf_L} P_e \frac{\alpha e^{-\alpha(x+w_A)}}{1 - e^{-\alpha w_A}}$$



System of differential equations,  $\partial/\partial t = 0$  :

$$\frac{1}{v_p} \frac{\partial i_p(x, t)}{\partial t} + \frac{\partial i_p(x, t)}{\partial x} = eFg(x, t), \quad i_p(x, t) = Fep(x, t)v_p,$$

$$\frac{1}{v_n} \frac{\partial i_n(x, t)}{\partial t} - \frac{\partial i_n(x, t)}{\partial x} = eFg(x, t), \quad i_n(x, t) = Fen_T(x, t)v_n,$$

Minority current injection neglected,  $i_p(-w_A) = 0$ ,  $i_n(0) = 0$ : ◀

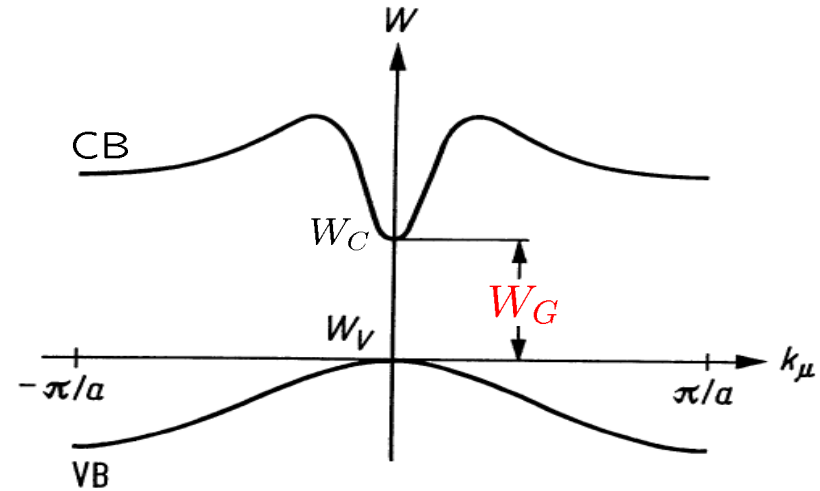
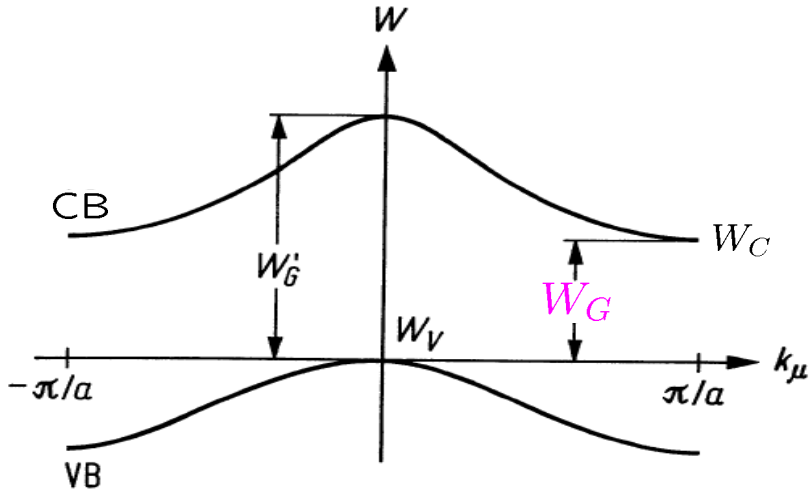
$$i = i_p(0) = i_n(-w_A) = \int_{-w_A}^0 eFg(x) dx = \frac{\eta e}{hf_L} P_e, \quad i = \frac{\eta e}{hf_L} P_e = SP_e$$

Each absorbed photon generates electron-hole pair  $\rightarrow$  transport of one elementary charge  $e$  through external circuit.

Rate of generated charges  $i/e = \eta P_e / (hf_L)$  photon absorption rate.



# Band Structure of Direct and Indirect Semiconductors



Indirect semicond. Smallest transition energy  $W_G$  for crystal momentum diff.  $\Delta k_\mu = \pi/a$ . Phonon required as collision partner  $\rightarrow$  Radiative transition unlikely. Examples: Elemental semiconductors Si, Ge

$$W_G = \begin{cases} 0.67 \text{ eV} \cong 1.85 \mu\text{m} & (\text{Ge}) \\ 1.13 \text{ eV} \cong 1.10 \mu\text{m} & (\text{Si}) \end{cases}$$

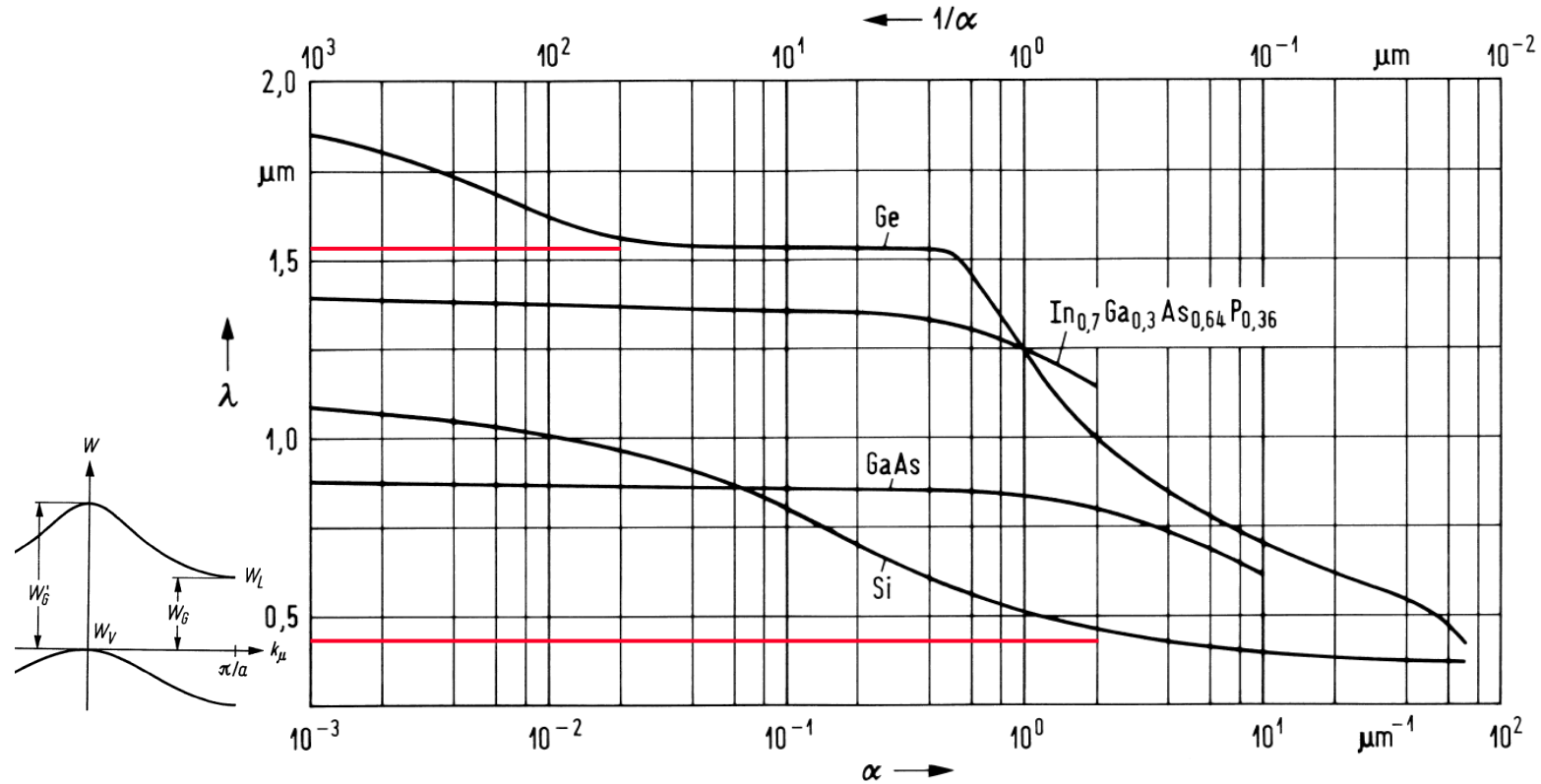
$$W'_G = \begin{cases} 0.8 \text{ eV} \cong 1.55 \mu\text{m} & (\text{Ge}) \\ 3.4 \text{ eV} \cong 0.36 \mu\text{m} & (\text{Si}) \end{cases}$$

Direct semicond. Smallest transition energy  $W_G$  for crystal momentum difference  $\Delta k_\mu = 0$ . No collision partner required  $\rightarrow$  Radiative transition likely. Examples: Compounds GaAs, InP, InGaAs

$$W_G = \begin{cases} 1.42 \text{ eV} \cong 0.87 \mu\text{m} & (\text{GaAs}) \\ 1.80 \text{ eV} \cong 0.69 \mu\text{m} & (\text{Ga}_{0.7}\text{Al}_{0.3}\text{As}) \\ 0.75 \text{ eV} \cong 1.65 \mu\text{m} & (\text{In}_{0.53}\text{Ga}_{0.47}\text{As}) \\ 1.35 \text{ eV} \cong 0.92 \mu\text{m} & (\text{InP}) \end{cases}$$



# Absorption Constants



Wavelength dependence of the absorption constant  $\alpha$  (penetration depth  $1/\alpha$ ) for several semiconductor materials

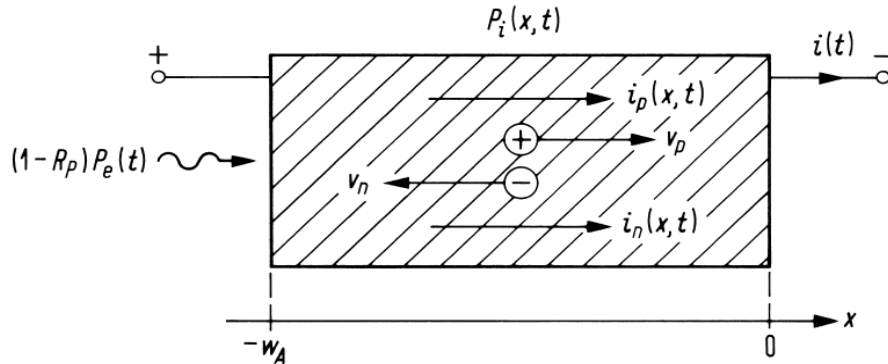
$$W_G = \begin{cases} 0,67 \text{ eV} \cong 1,85 \mu\text{m} & (\text{Ge}) \\ 1,13 \text{ eV} \cong 1,10 \mu\text{m} & (\text{Si}) \end{cases}$$

$$W'_G = \begin{cases} 0,8 \text{ eV} \cong 1,55 \mu\text{m} & (\text{Ge}) \\ 3,4 \text{ eV} \cong 0,36 \mu\text{m} & (\text{Si}) \end{cases}$$

$$W_G = \begin{cases} 1,42 \text{ eV} \cong 0,87 \mu\text{m} & (\text{GaAs}) \\ 1,80 \text{ eV} \cong 0,69 \mu\text{m} & (\text{Ga}_{0,7}\text{Al}_{0,3}\text{As}) \\ 0,75 \text{ eV} \cong 1,65 \mu\text{m} & (\text{In}_{0,53}\text{Ga}_{0,47}\text{As}) \\ 1,35 \text{ eV} \cong 0,92 \mu\text{m} & (\text{InP}) \end{cases}$$



# pin Photodiode — Dynamics



$$\eta = (1 - R_P) (1 - e^{-\alpha w_A})$$

$$eFg(x, t) = \frac{\eta e}{hf_L} P_e(t) \frac{\alpha e^{-\alpha(x+w_A)}}{1 - e^{-\alpha w_A}}$$

Absorption layer of a pin-photodiode.  $P_e$  incident external light power,  $R_P$  power reflection coefficient,  $i(t)$  external short-circuit current,  $P_i$  internal optical power;  $i_p$ ,  $i_n$  convection currents of electrons and holes;  $v_p$ ,  $v_n$  saturation drift velocities,  $w_A$  length of absorption region

Differential equations to be solved for ext. short-circuit current: ►

$$\frac{1}{v_p} \frac{\partial i_p(x, t)}{\partial t} + \frac{\partial i_p(x, t)}{\partial x} = eFg(x, t), \quad i_p(x, t) = Fep(x, t)v_p,$$

$$\frac{1}{v_n} \frac{\partial i_n(x, t)}{\partial t} - \frac{\partial i_n(x, t)}{\partial x} = eFg(x, t), \quad i_n(x, t) = Fen_T(x, t)v_n,$$

$$i(t) = \frac{1}{w_A} \int_{-w_A}^0 [i_n(x, t) + i_p(x, t)] dx$$

# pin Photodiode — Dynamics. Impulse Response (1)

Integrate over interval  $-\Delta t \leq t \leq \Delta t$ , current before  $\delta$ -impulse of generation rate  $g(x, t) \sim \delta(t)$  is zero, spatial dependency of time integral of finite current disappears for  $\Delta t \rightarrow 0$ , i. e.,

$$\int_{-\Delta t}^{+\Delta t} \frac{\partial i_p}{\partial x} dt = \frac{\partial}{\partial x} \int_{-\Delta t}^{+\Delta t} i_p dt \rightarrow 0 \quad \text{for} \quad \Delta t \rightarrow 0,$$

because  $i_p(x, t)$  has no singularity in time, and free charge carriers disappear,  $P_e(t) = \delta(t)$ ,

$$\frac{1}{v_p} \int_{-\Delta t}^{+\Delta t} \frac{\partial i_p}{\partial t} dt + \int_{-\Delta t}^{+\Delta t} \frac{\partial i_p}{\partial x} dt = \frac{\eta e}{h f_L} \frac{\alpha e^{-\alpha(x+w_A)}}{1 - e^{-\alpha w_A}} \int_{-\Delta t}^{+\Delta t} \delta(t) dt \quad \text{f. } \Delta t \rightarrow 0,$$

$$\frac{1}{v_p} \left( i_p(x, +0) - \underbrace{i_p(x, -0)}_{=0} \right) + \underbrace{\frac{\partial}{\partial x} \int_{-\Delta t}^{+\Delta t} i_p(x, t) dt}_{=0 \text{ für } \Delta t \rightarrow 0} = \frac{\eta e}{h f_L} \frac{\alpha e^{-\alpha(x+w_A)}}{1 - e^{-\alpha w_A}}$$





## pin Photodiode — Dynamics. Impulse Response (2)

$$\frac{1}{v_p} \left( i_p(x, +0) - \underbrace{i_p(x, -0)}_{=0} \right) + \underbrace{\frac{\partial}{\partial x} \int_{-\Delta t}^{+\Delta t} i_p(x, t) dt}_{=0 \text{ für } \Delta t \rightarrow 0} = \frac{\eta e}{h f_L} \frac{\alpha e^{-\alpha(x+w_A)}}{1 - e^{-\alpha w_A}}$$

Limit  $\Delta t \rightarrow 0$  leads to „convection currents“ at time  $t = +0$  (IC).  
 $i_p(x, +0) = i_n(x, +0)$  holds because carriers are generated by pairs:

$$\frac{1}{v_p} i_p(x, +0) = \frac{1}{v_n} i_n(x, +0) = \frac{\eta e}{h f_L} \frac{\alpha \exp[-\alpha(x + w_A)]}{1 - \exp(-\alpha w_A)} \quad \text{U}$$

$g(x, t) = 0$  f.  $t > 0$ . Homogeneous DE solved by arbitrary functions:

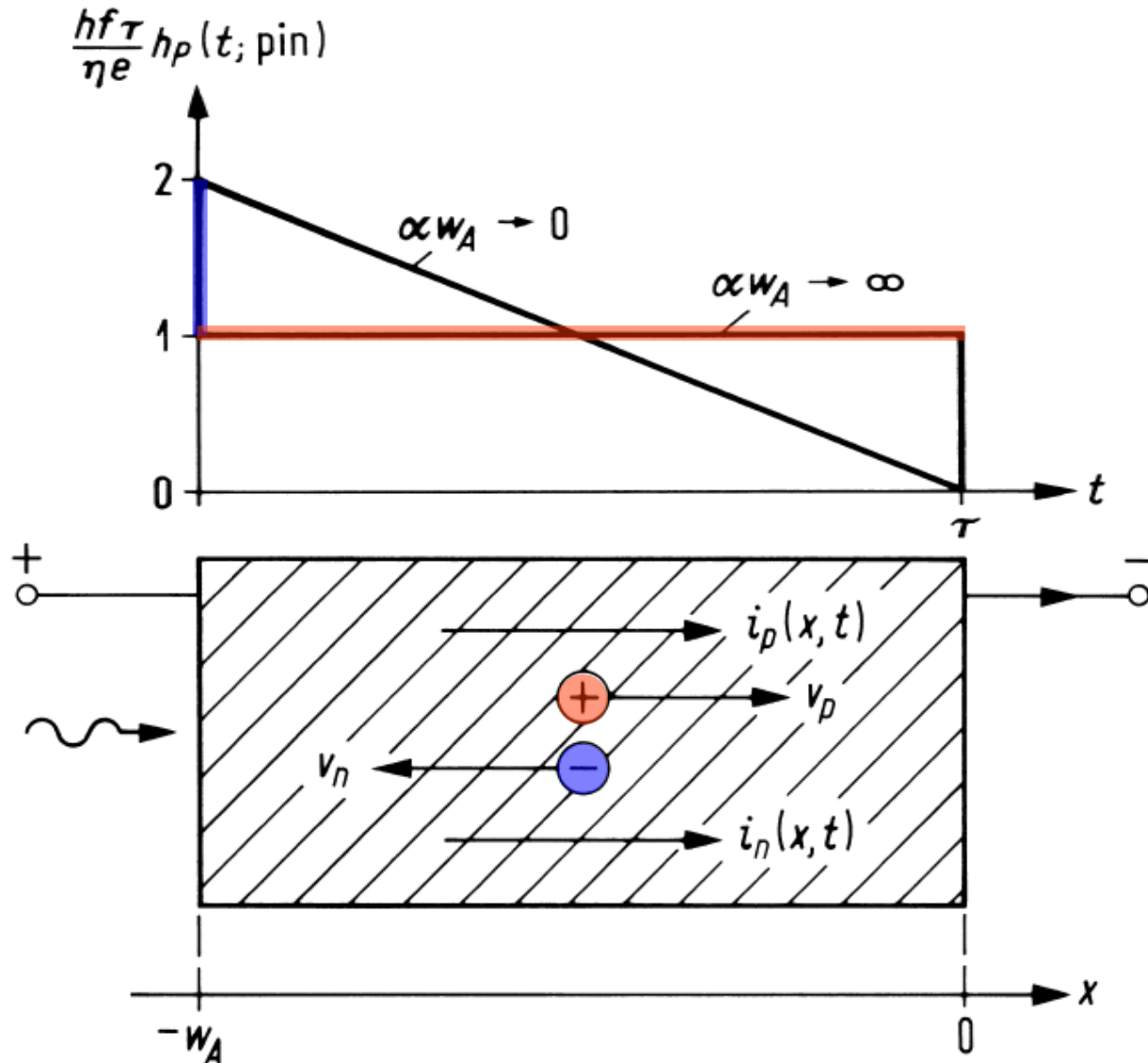
$$\frac{1}{v_p} \frac{\partial i_p}{\partial t} + \frac{\partial i_p}{\partial x} = 0 \quad \longrightarrow \quad i_p(x, t) = i_p(x - v_p t), \quad i_n(x, t) = i_n(x + v_n t),$$

$$\frac{\partial i_p}{\partial t} = \frac{\partial i_p(x - v_p t)}{\partial(x - v_p t)} \frac{\partial(x - v_p t)}{\partial t} = -v_p \frac{\partial i_p(x - v_p t)}{\partial(x - v_p t)},$$

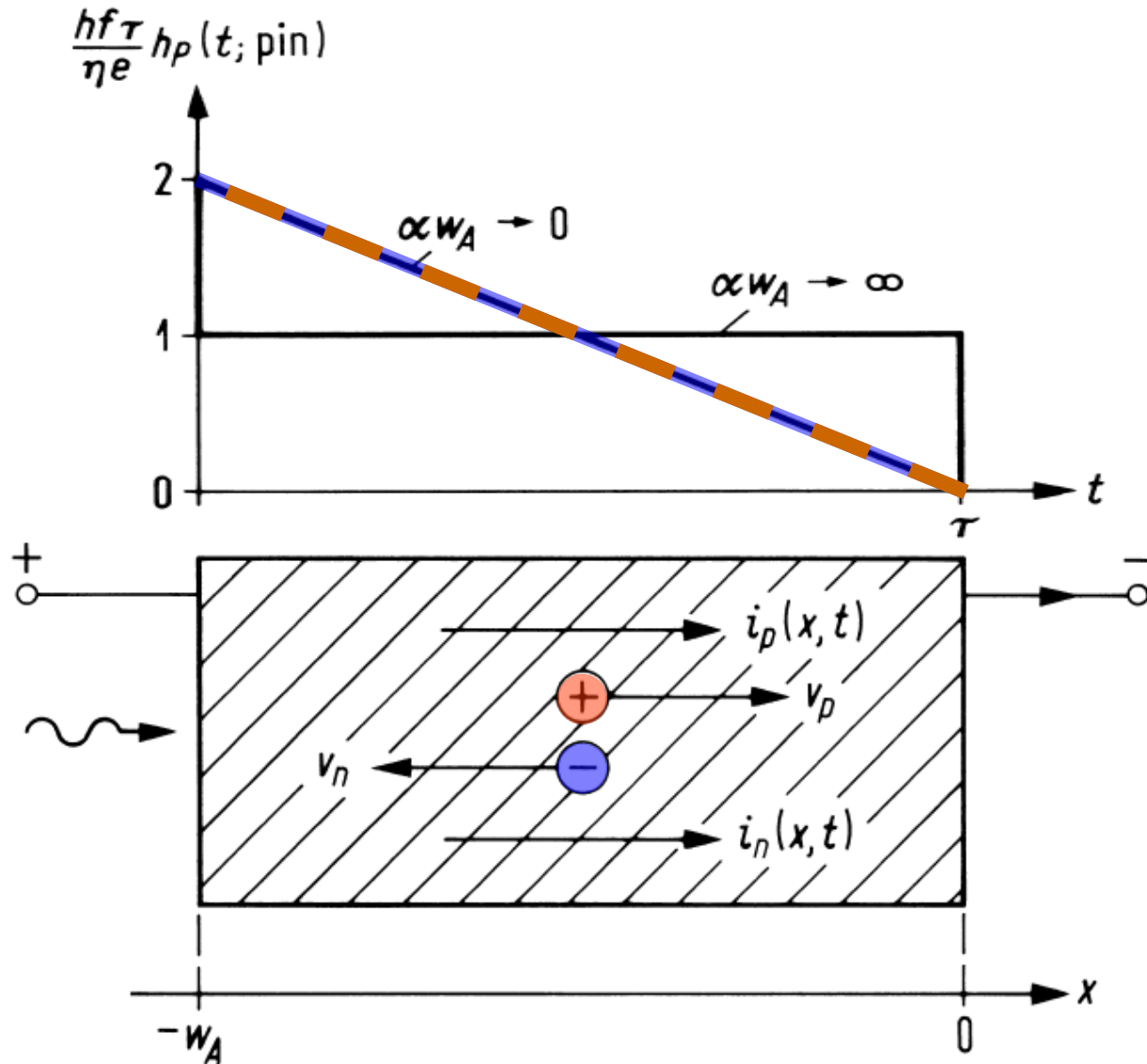
$$\frac{\partial i_p}{\partial x} = \frac{\partial i_p(x - v_p t)}{\partial(x - v_p t)} \frac{\partial(x - v_p t)}{\partial x} = \frac{\partial i_p(x - v_p t)}{\partial(x - v_p t)}$$



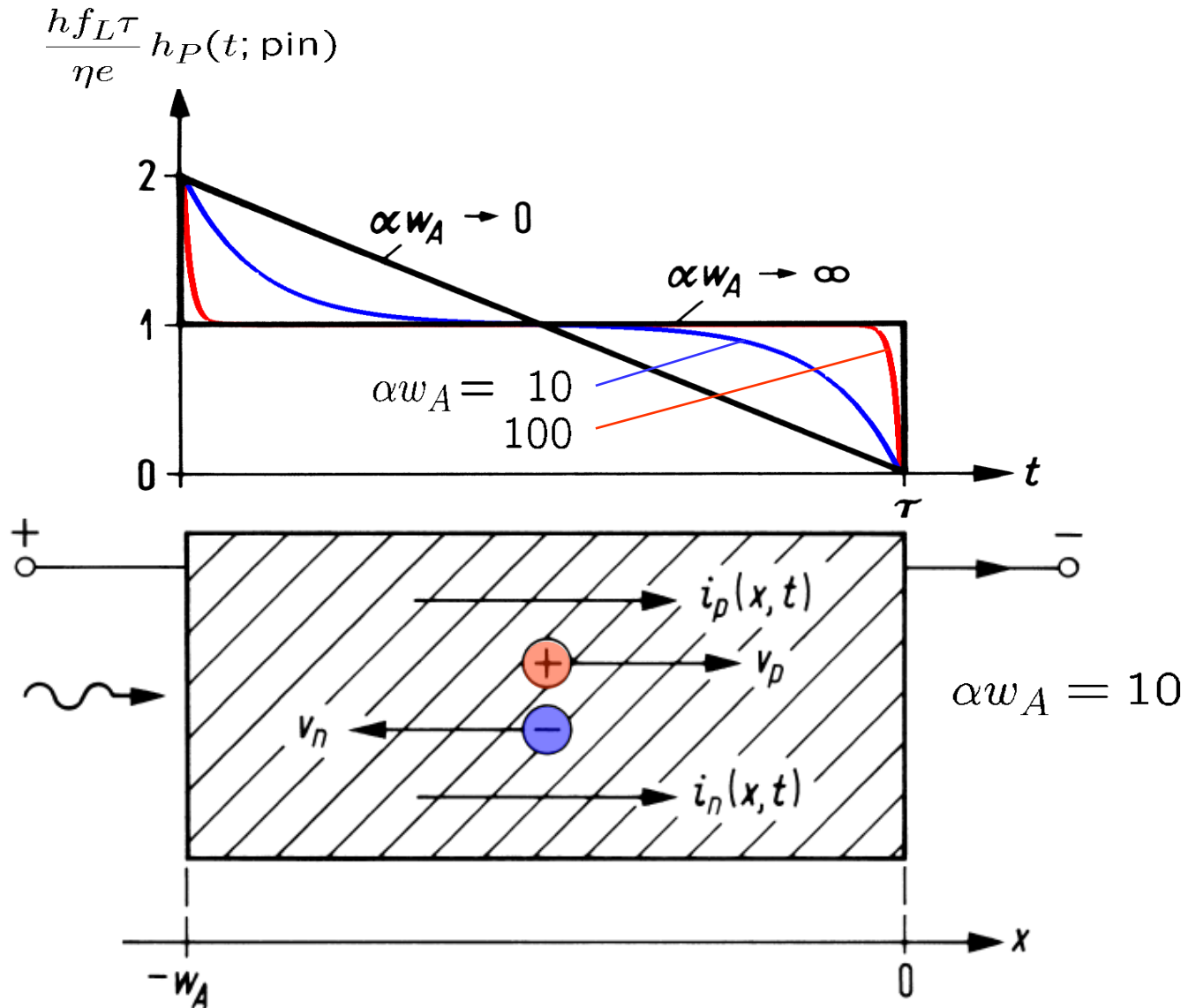
# pin Photodiode — Impulse Response Strong Absorption



# pin Photodiode — Impulse Response Weak Absorpt. ( $v_n = v_p$ )



# pin Photodiode — Impulse Response Fair Absorpt. ( $v_n = v_p$ )



# LECTURE 15



# pin Photodiode — Transit Time Cutoff Frequency

Short-circuit current spectrum  $I(f; \text{pin})$  for light power:

$$P_e(t) = P_0 + P_1 \cos(\omega t) \quad (P_0 \geq P_1)$$

Limiting cases strong and weak absorption, for weak absorption

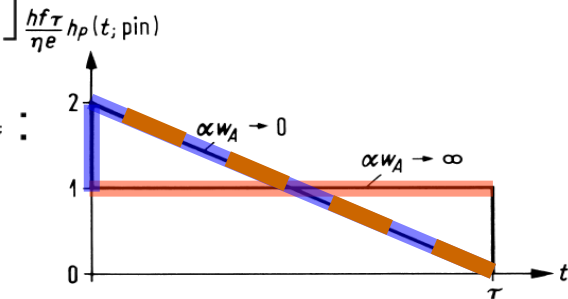
$\tau_n = \tau_p = \tau$  holds:

$$\frac{I(f; \text{pin})}{I(0; \text{pin})} = e^{-j\omega\tau_p/2} \frac{\sin(\omega\tau_p/2)}{\omega\tau_p/2} \quad \text{für } \alpha w_A \rightarrow \infty$$

$$\frac{I(f; \text{pin})}{I(0; \text{pin})} = \frac{1}{j\omega\tau/2} \left[ 1 - e^{-j\omega\tau/2} \frac{\sin(\omega\tau/2)}{\omega\tau/2} \right] \quad \text{für } \alpha w_A \rightarrow 0$$

3-dB cutoff frequency from  $\left| \frac{I(f_{3\text{dB}}; \text{pin})}{I(0; \text{pin})} \right| = \frac{1}{\sqrt{2}}$ :

$$f_{3\text{dB}} = \begin{cases} 0.44/\tau_p & \text{for } \alpha w_A \rightarrow \infty \\ 0.55/\tau & \text{für } \alpha w_A \rightarrow 0, \quad \tau_n = \tau_p = \tau \end{cases}$$





# pin Photodiode — Quantum Efficiency

Quantum efficiency for weak absorption  $\alpha w_A \rightarrow 0$ :

$$\eta = \frac{P_i(-w_A, t) - P_i(0, t)}{P_e(t)} = (1 - R_P) \left(1 - e^{-\alpha w_A}\right) \underset{\alpha w_A \rightarrow 0}{=} (1 - R_P) \alpha w_A$$

3-dB cutoff frequency for  $\alpha w_A \rightarrow 0$ :

$$f_{3\text{dB}} = 0.55/\tau$$

Product of quantum efficiency and cutoff frequency:

$$\eta f_{3\text{dB}} = 0.55 (1 - R_P) \alpha v \quad \text{for } \alpha w_A \rightarrow 0$$

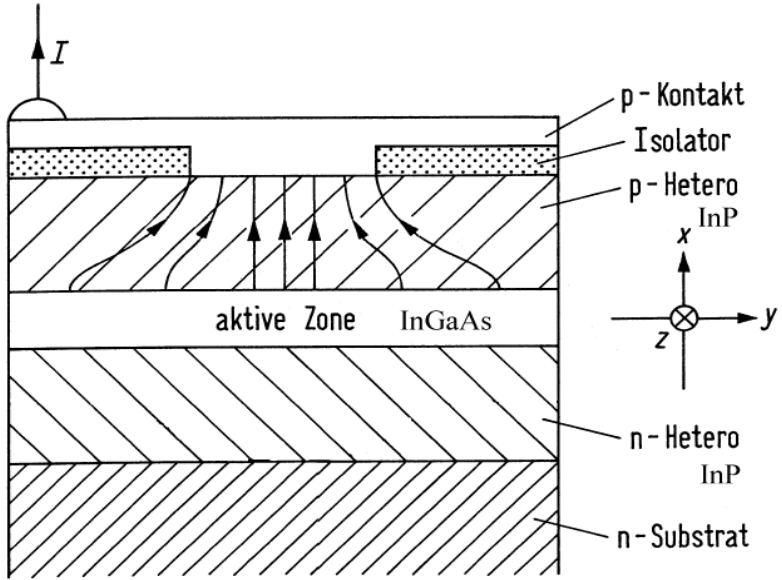
$\eta f_{3\text{dB}}$  depends for  $R_P = 0$  only on material properties  $\alpha$ ,  $v$  (power attenuation constant, saturation drift velocities of carriers).

For InGaAs at  $\lambda = 1.55 \mu\text{m}$  ( $\alpha = 0.68 \mu\text{m}^{-1}$ ,  $v = (v_n + v_p)/2 = 56.5 \mu\text{m/ns}$ ):  $\eta f_{3\text{dB}} = 21 \text{ GHz}$ ; at  $\lambda = 1.36 \mu\text{m}$  ( $\alpha = 1.16 \mu\text{m}^{-1}$ ,  $v = 56.5 \mu\text{m/ns}$ ):  $\eta f_{3\text{dB}} = 36 \text{ GHz}$ .



# pin Photodiode — Edge Coupling (1)

For  $\alpha w_A \rightarrow 0$  better performance achieved by irradiating light  $\parallel$  to pn-junction into absorption zone.



- act. InGaAs absorption zone
- n-InP/p-InP hetero layers
- reverse voltage
- InP/InGaAs/InP slab WG

Pin-diode with edge-coupling of light,  $w_A$  is the height of the active zone.  $x$ -axis: direction of current flow;  $z$ -axis: direction of light propagation (Aktive Zone = active zone, p-Kontakt = p-contact, Isolator = insulator, n-substrat = n-substrate).

For InGaAs layer with thickness  $w_A = 0.2 \mu\text{m}$ : Field confinement

$$\text{factor } \Gamma = \frac{\text{power in core}}{\text{power in cross-section}} = 0.4$$

This means difficult coupling conditions because of small WG cross-section!



## pin Photodiode — Edge Coupling (2)



Eff. absorption constant  $\alpha\Gamma$  for vertical fundamental mode. Length  $L$  of absorption zone in  $z$ -direction, coupling efficiency  $\eta_{\text{coupl}}$ . Quantum efficiency:

$$\eta = \eta_{\text{coupl}} \left(1 - e^{-\alpha\Gamma L}\right)$$

Quantum efficiency ( $\alpha = 0.68 \mu\text{m}^{-1}$ ,  $\Gamma = 0.4$ ,  $L > 10 \mu\text{m}$ ):

$$\eta \approx \eta_{\text{coupl}} \quad \text{because} \quad e^{-\alpha\Gamma L} < 0.066$$

$\eta_{\text{coupl}} \approx 0.5$  realistic. Transit-time cutoff frequency for small  $w_A$ :

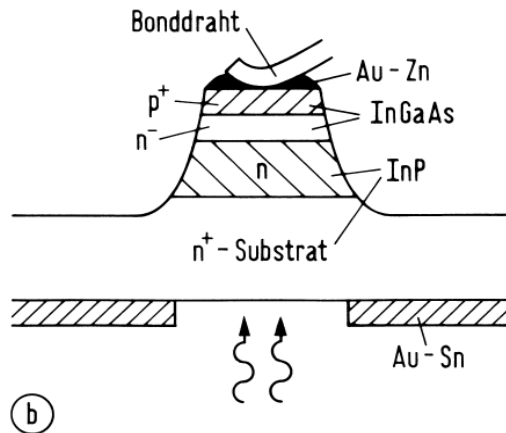
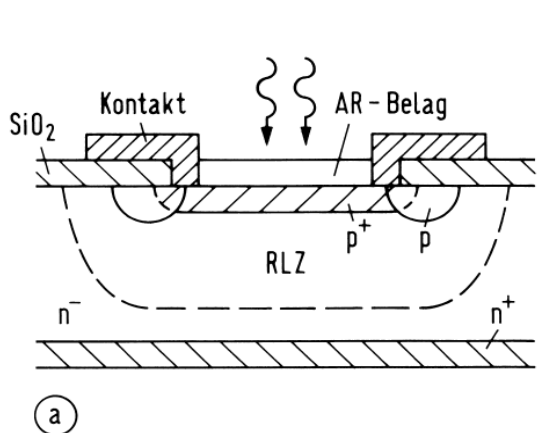
$$f_{3\text{dB}} = 0.55/\tau \quad \text{for} \quad \alpha w_A \rightarrow 0, \quad \tau_n = \tau_p = \tau$$

$\eta \approx 0.5$  independently of  $f_{3\text{dB}}$  and  $\lambda$ . With  $w_A = 0.2 \mu\text{m}$ :

$$f_{3\text{dB}} = 124 \text{ GHz}$$



# pin Photodiode — Devices, Si Planar and InGaAs-Mesa (1)



Operation for  
 $0.92 \mu\text{m} < \lambda < 1.65 \mu\text{m}$

Cutoff frequency  
 $65 \dots 100 \text{ GHz}$   
 for  $L_S \leq 0.2 \text{ nH}$

Pin-photodiodes. (a) Planar Si photodiode (b) InGaAs/InP photodiode with mesa structure and illumination through the InP substrate (AR-Belag = anti-reflection coating, RLZ Raumladungszone = depletion region, Kontakt = contact. Bonddraht = bond wire).

**Abrupt pn-junction.** Doping concentrations  $n_A$ ,  $n_D$ , intrinsic  $n_i$ , temperature voltage  $U_T = kT/e$ , inbuilt voltage  $U_D$ , space charge region reverse voltage  $U > 0$ , junction width  $w$ , capacitance  $C_{\text{sp}}$ :

$$w = \sqrt{\frac{2\epsilon_0\epsilon_r(U_D + U)}{e} \left( \frac{1}{n_A} + \frac{1}{n_D} \right)},$$

$$C_{\text{sp}} = \frac{\epsilon_0\epsilon_r F}{w},$$

$$U_D = U_T \ln \frac{n_A n_D}{n_i^2}.$$



## pin Photodiode — Devices, Si Planar (2)

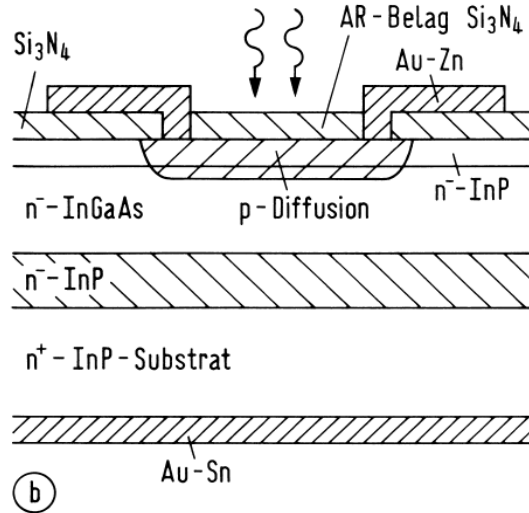
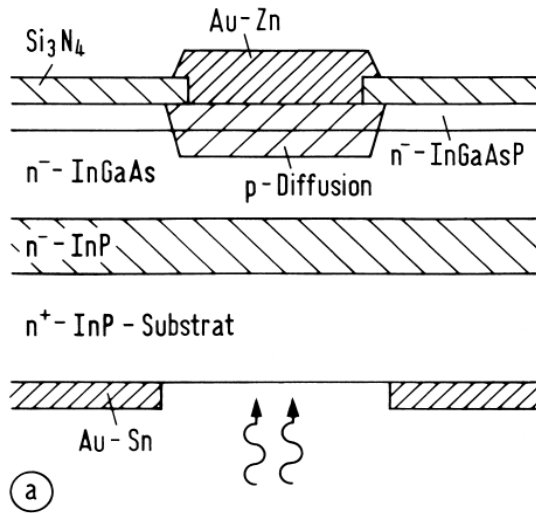
- Short- $\lambda$  mostly Si, absorption length  $1/\alpha = 15 \mu\text{m}$  @  $\lambda = 0.85 \mu\text{m} \rightarrow \eta \approx 0.5$
- AR coating  $\text{SiO}_2$ ,  $\text{Si}_3\text{N}_4$ . Light in thin ( $< 1 \mu\text{m}$ ) cover layer hardly absorbed. Absorption zone from  $n^-$ -material ( $n_D = 13 \times 10^{14} \text{cm}^{-3}$ )
- Light in direction of faster carriers (Si:  $n_T$ ; InGaAs:  $p$ )
- p guard ring to prevent breakdown at edges
- Width space-charge region  $10 \mu\text{m}$  for  $U = 10 \text{V}$ ,  $n_D = 1.3 \times 10^{14} \text{cm}^{-3} \ll n_A$ ,  $\epsilon_0 = 8.85 \times 10^{-12} \text{Fm}^{-1}$ ,  $\epsilon_r = 11.7$
- With  $v = (v_n + v_p)/2 = 64 \mu\text{m} / \text{ns}$  the transit-time cutoff frequency is near 3 GHz:

$$\eta f_{3\text{dB}} = 0.55 (1 - R_P) \alpha v$$

- $F = (200 \mu\text{m})^2 \cong (16 \mu\text{m} \text{ diameter})$ ,  $R_S + R_a = 60 \Omega \rightarrow RC$  cutoff frequency 6.4 GHz  $\rightarrow$  transit-time limited



# pin Photodiode — Devices, InGaAs Planar (3)



Planar InGaAs/InP pin-photodiodes. (a) Illumination through the substrate (b) illumination from top, AR-Belag = anti-reflection coating

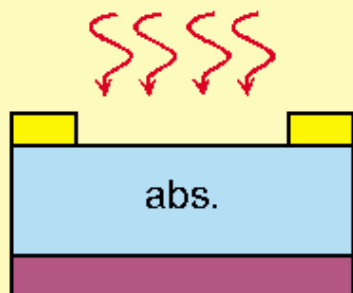




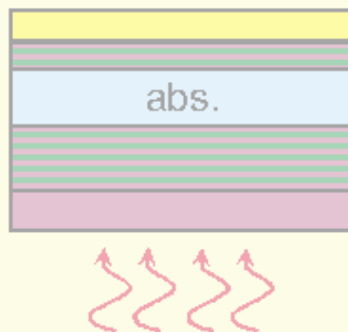
# Design of Photodetectors: Overview

## vertically illuminated

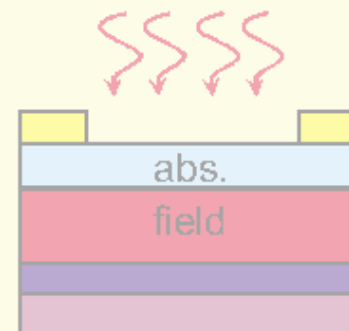
surface illumination



resonant structures



uni-travelling carrier PD

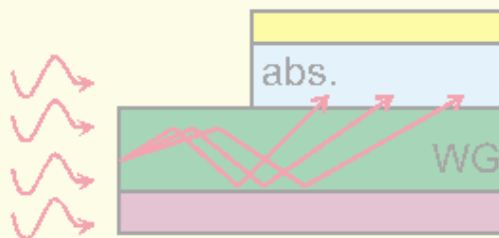


## edge coupled

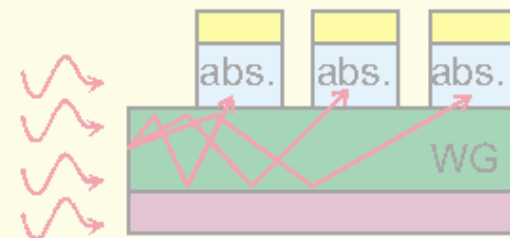
waveguide detector



waveguide-fed detector



distributed photodetector



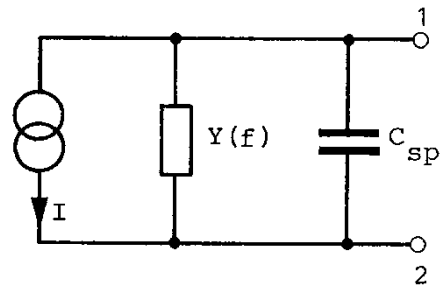
# Shot Noise

Shot noise, if quantization of charges manifest:

1. Transition of charges across junctions
2. Transition of charges between electrodes in vacuum
3. Generation of charges through inner photoelectric effect

If RV “carrier number in observation time” statistically independent, then Poisson probability that for  $\bar{n}$  (average)  $n$  photons:

$$p_n(n) = \frac{\bar{n}^n}{n!} e^{-\bar{n}}, \quad \sigma_n^2 = \overline{(n - \bar{n})^2} = \overline{\delta n^2} = \overline{n^2} - (\bar{n})^2 = \bar{n}$$



Small-signal equivalent circuit of a pn-junction with shot noise current  $I$ . Diffusion admittance  $Y(f)$ , junction capacitance  $C_{sp}$

Shot noise, two- and one-sided power spectrum:

$$\Theta_i(f) = \bar{i}^2 \delta(f) + e\bar{i},$$

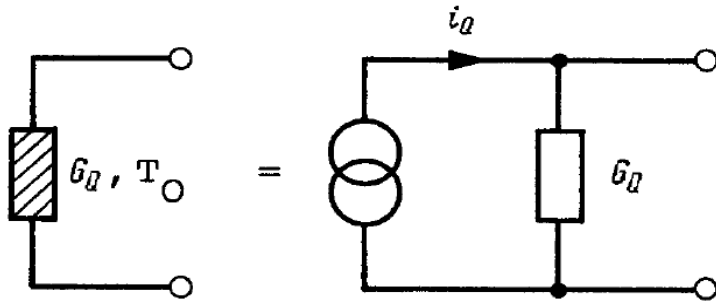
$$w_i(f) = 2\bar{i}^2 \delta(f) + 2e\bar{i}.$$

Current generator with RMS phasor  $I$  in  $\Delta f$ :

$$\overline{|I|^2} = 2e\bar{i}\Delta f$$



# Thermal Noise



Temperature  $T$ , electrons move randomly  $\rightarrow$  random current, even without voltage. PD load resistance at amplifier input adds noise  $\rightarrow$  **thermal noise, Johnson or Nyquist noise.**

Equivalent circuit of a conductance  $G_Q$  with thermal noise

RMS noise phasors discussed in previous slide. Equivalent short-circuit noise phasor  $i_Q$  of conductance  $G_Q$  at temperature  $T_0$  has an expectation  $\overline{i_Q} = 0$  and a second moment:

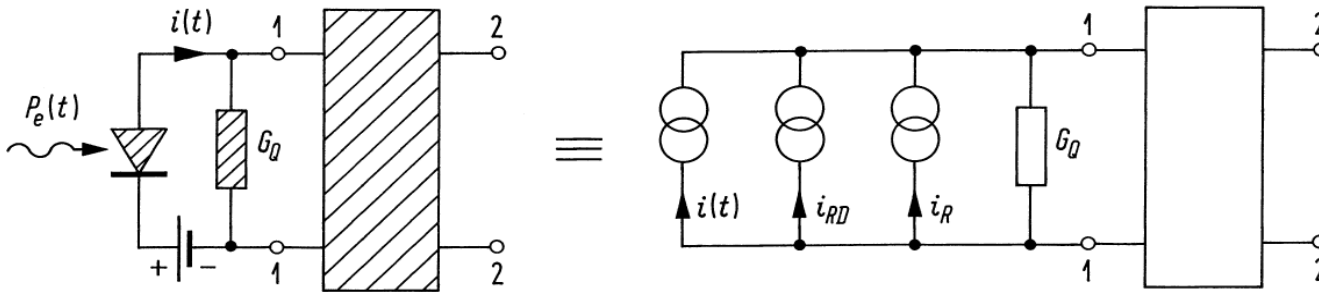
$$\overline{|i_Q|^2} = 4kT_0G_Q df, \quad T_0 = 293 \text{ K}$$

**Shot noise** for comparison:

$$\overline{|i_{RD}|^2} = 2e\bar{i} df$$



# Amplifier Noise Figure



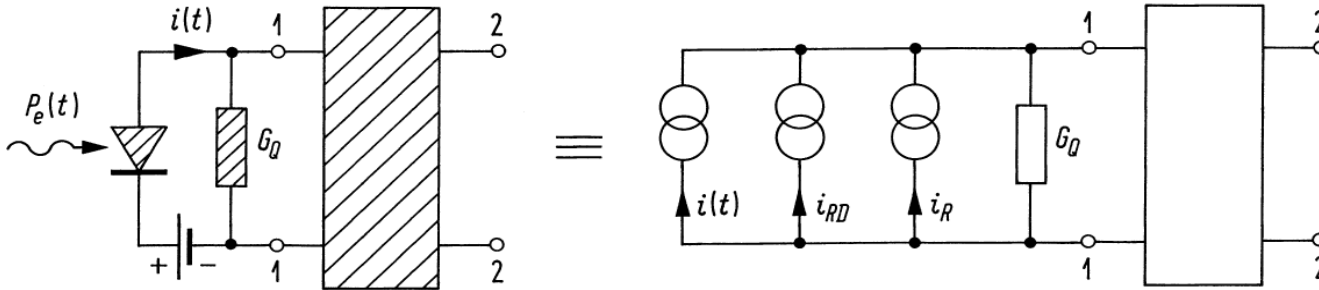
**Fig. 7.1.** Schematic of an optical receiver with pin-photodiode, source conductance  $G_Q$  and amplifier (noisy components are hatched).  $i_{RD}$  specifies the shot noise of the pin-photodiode,  $i_R$  represents the noise of the source conductance and of the amplifier

Electronic amplifier connected to source with admittance  $Y_Q = G_Q + jB_Q$ . Amplifier noise described by fictitious increase of actual conductance temperature  $T_0$  to temperature  $FT_0 = T_0 + T_R$ , then amplifier (noise temperature  $T_R$ ) regarded as noiseless. Equivalent short-circuit noise current:

$$\overline{|i_R|^2} = 4k (FT_0) G_Q df, \quad F = \frac{\overline{|i_R|^2}}{\overline{|i_Q|^2}} = 1 + \frac{T_R}{T_0},$$

$$F = \frac{\text{total output noise power in } df}{\text{total output noise power for noiseless two-port in } df}$$

# pin Photodiode Receiver Limits



**Fig. 7.1.** Schematic of an optical receiver with pin-photodiode, source conductance  $G_Q$  and amplifier (noisy components are hatched).  $i_{RD}$  specifies the shot noise of the pin-photodiode,  $i_R$  represents the noise of the source conductance and of the amplifier

Noise sources uncorrelated  $\rightarrow$  noise powers added. Average signal current  $i_S \equiv \bar{i} = S\bar{P}_e$ ,  $S = \eta e / (hf_L)$ . SNR  $\gamma$  for direct reception in el. bandwidth  $df = B$  ( $\overline{|i_{RD}|^2} = 2ei_S B$ ,  $\overline{|i_R|^2} = 4kFT_0 G_Q B$ ):

$$\gamma = \frac{P_S}{P_R} = \frac{i_S^2}{\overline{|i_{RD}|^2} + \overline{|i_R|^2}} = \frac{\eta \bar{P}_e}{2hf_L B} \frac{1}{1 + 4kFT_0 G_Q / (2ei_S)}$$

If thermally limited  $\overline{|i_R|^2} \gg \overline{|i_{RD}|^2}$ . **Shot noise limit**  $\overline{|i_{RD}|^2} \gg \overline{|i_R|^2}$ :

$$\gamma_{\max} = \frac{\eta \bar{P}_e}{hf_L \times \left(2B = f_t = \frac{1}{T_t}\right)} = \eta N_e \quad (\text{shot-noise limit, } \frac{4kFT_0 G_Q}{2ei_S} \ll 1)$$

## pin Photodiode Quantum (Shot) Noise Limit

$$\gamma = \frac{P_S}{P_R} = \frac{i_S^2}{|i_{RD}|^2 + |i_R|^2} = \frac{\eta \overline{P_e}}{2hf_L B} \frac{1}{1 + 4kFT_0 G_Q / (2ei_S)}$$

$$\gamma_{\max} = \frac{\eta \overline{P_e}}{hf_L \cdot 2B} = \eta N_e \quad (\text{shot-noise limited, } \frac{4kFT_0 G_Q}{2ei_S} \ll 1)$$

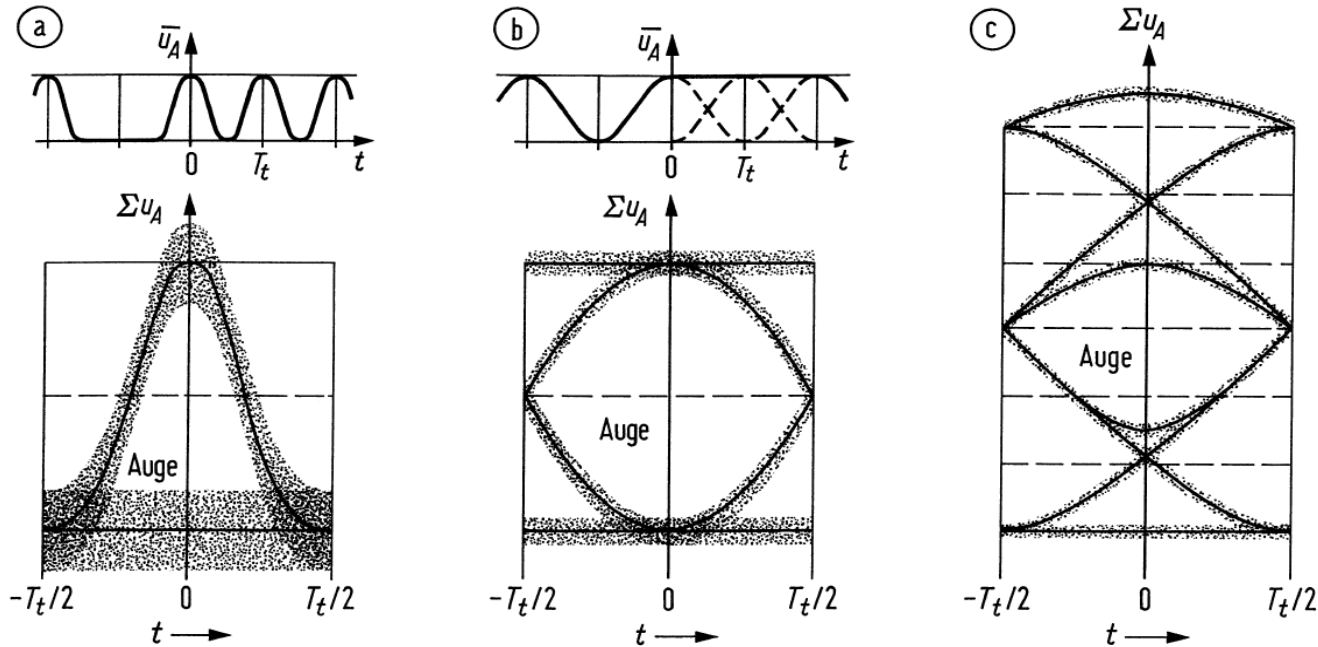
Bit period  $T_t = 1/f_t = 1/(2B)$ . Energy per 1-bit  $\overline{P_e} T_t \rightarrow$  number of received photons  $N_e = \overline{P_e} T_t / (hf_L)$  (absorbed:  $\eta N_e$ ). SNR = 20 dB for  $N_e \approx 100$  photons ( $\eta \approx 1$ ). Several 1 000 photons required for  $\gamma \hat{=} 20$  dB when thermal noise dominating. At  $1.55 \mu\text{m}$ , receiver operating at  $f_t = 10$  Gbit/s,  $N_e = 100$  when  $\overline{P_e} \approx 130$  nW.

El. ampl. noise prevents shot noise limit for pin-PD receiver. With OA,  $i_S$  large enough. Noise added (minimum for direct reception  $F = 2$ ). Shot-noise limited SNR somewhat smaller, but achievable:

$$\gamma_{\text{OA max}} = \frac{1}{2} \frac{\overline{P_e}}{hf_L \cdot 2B} = \frac{\gamma_{\max}}{2\eta} = \frac{1}{2} N_e$$



# Eye Diagram



**Fig. 7.2.** Eye diagrams for RZ (return to zero) pulses, sampling time  $t = 0$ ; solid lines: without noise. (a) large noise, no impulse overlap (b) optimum case: small noise, impulse overlap, but no intersymbol interference at sampling time (c) low noise, strong impulse overlap, strong intersymbol interference at sampling time. Auge = eye





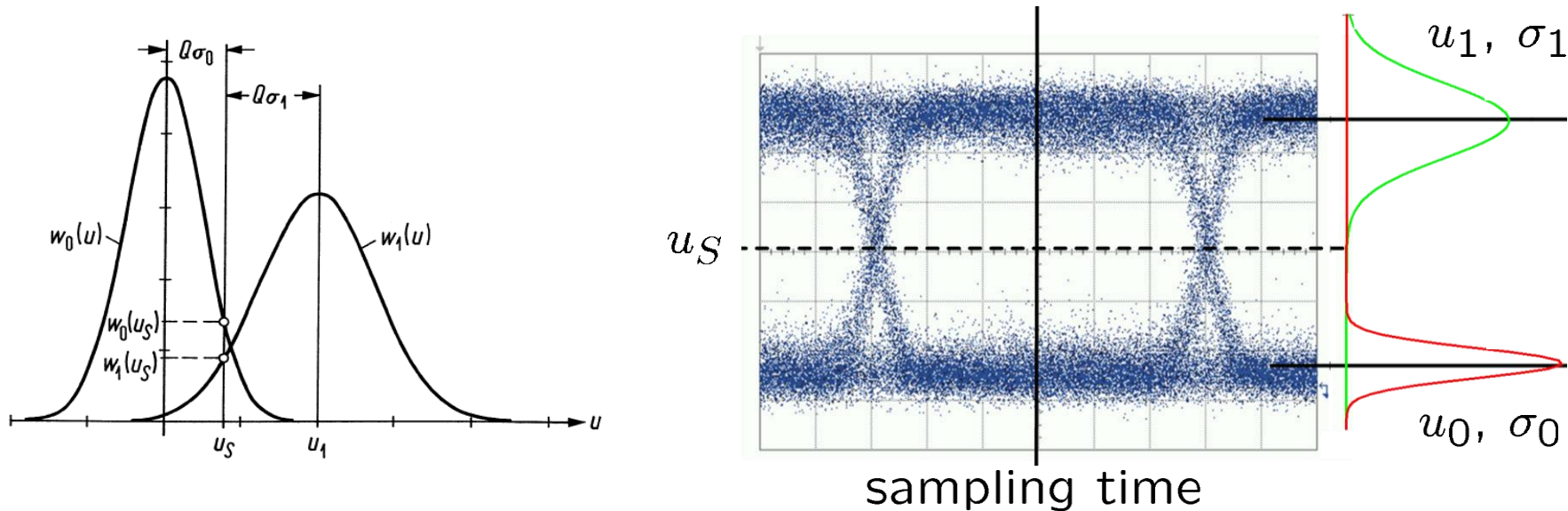
# Detection Errors by Noise (1)

Voltage at decision circuit ( $u(t) \equiv u_A(t)$ ):

$$u(t) = u_{R0}(t) \quad (0\text{-bit received}),$$

$$u(t) = u_{R1}(t) + u_1 h_A(t) \quad (1\text{-bit received}).$$

Gaussian noise voltages with expectation zero  $u_{R0}(t)$ ,  $u_{R1}(t)$ . Equalizer produces impulse  $h_A(t)$ , normalized such that  $h_A(0) = 1$  at sampling time  $t = 0$ . Expectation  $u_1$  at sampling time.



Probability densities  $w_0(u)$ ,  $w_1(u)$  of the sampled input voltage of the decision circuit for the receive symbols zero, one.  $\sigma_0$ ,  $\sigma_1$  standard deviations,  $u_1$  expectation of voltage for a received one,  $u_S$  specific choice of decision threshold fixed by the bit error parameter  $Q$



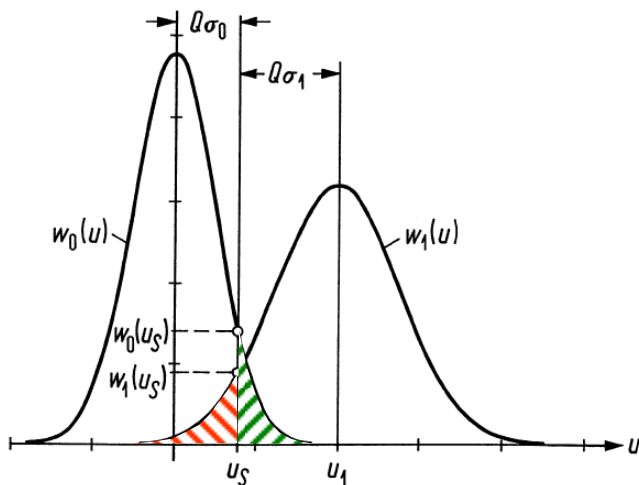
## Detection Errors by Noise (2)

Probability density functions (pdf) for decision circuit voltages at sampling time  $w_0(u)$ ,  $w_1(u)$  (0 and 1 received, respectively):

$$w_0(u) = \frac{1}{\sqrt{2\pi\sigma_0^2}} \exp\left(-\frac{u^2}{2\sigma_0^2}\right), \quad \bar{u} = 0, \quad \overline{(u - \bar{u})^2} = \overline{u_{R0}^2} = \sigma_0^2,$$

$$w_1(u) = \frac{1}{\sqrt{2\pi\sigma_1^2}} \exp\left[-\frac{(u-u_1)^2}{2\sigma_1^2}\right], \quad \bar{u} = u_1, \quad \overline{(u - \bar{u})^2} = \overline{u_{R1}^2} = \sigma_1^2.$$

$\sigma_1^2 > \sigma_0^2$ , because logical 1 transmitted with higher power  $\rightarrow$  larger PD shot noise. Usually,  $1 < \sigma_1^2/\sigma_0^2 \leq 2$ .



Zero:  $u < u_S$ . One:  $u > u_S$ . Prob. that 1 wrong:  $p(1d|0r)$ ; 0 wrong:  $p(0d|1r)$ . Receiving prob.  $p(0r)$ ,  $p(1r)$ . Bit error probability (BER, bit error ratio):

$$\text{BER} = p(1r)p(0d|1r) + p(0r)p(1d|0r),$$

$$p(0r) + p(1r) = 1$$



# Detection Errors by Noise (3)

Minimum bit error probability:

$$\text{BER} = p(1r) \int_{-\infty}^{u_S} w_1(u) du + p(0r) \int_{u_S}^{\infty} w_0(u) du,$$

$$\frac{\partial \text{BER}}{\partial u_S} = p(1r)w_1(u_S) - p(0r)w_0(u_S) \stackrel{!}{=} 0,$$

$$\rightarrow p(1r)w_1(u_S) = p(0r)w_0(u_S)$$

Optimum threshold (note:  $u_S - u_1 = \pm \sqrt{(u_S - u_0)^2}$ ):

$$p(1r) \frac{1}{\sqrt{2\pi\sigma_1^2}} \exp\left(-\frac{(u_S - u_1)^2}{2\sigma_1^2}\right) = p(0r) \frac{1}{\sqrt{2\pi\sigma_0^2}} \exp\left(-\frac{(u_S - u_0)^2}{2\sigma_0^2}\right)$$

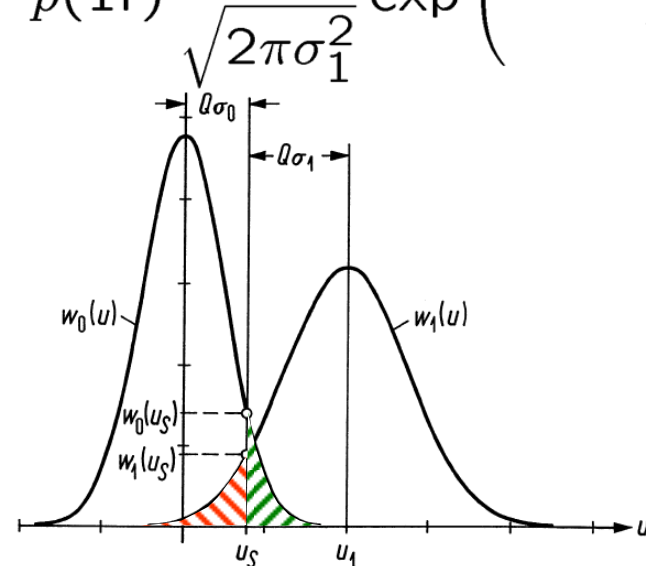
Threshold  $u_S = \frac{\sigma_0 u_1 + \sigma_1 u_0}{\sigma_0 + \sigma_1}$ , if  $\frac{p(1r)}{\sigma_1} = \frac{p(0r)}{\sigma_0}$ .

In practice:

$$1 < \sigma_1/\sigma_0 \leq \sqrt{2}, \quad \sigma_1 \approx \sigma_0$$

$$p(1r) = \frac{\sigma_1}{\sigma_0} p(0r) \gtrsim p(0r),$$

$$p(1r) \approx p(0r) \approx 1/2$$



# Bit-Error Parameter (Signal Quality Factor) and SNR

Connection between SNR  $\gamma$  at decision circuit (mean and RMS value measured) and bit error parameter  $Q$ ?

No intersymbol interference, bit rate  $f_t$ , clock period  $T_t = 1/f_t$ , el. signal bandwidth  $B = f_t/2$ . Average el. power at decision circuit:

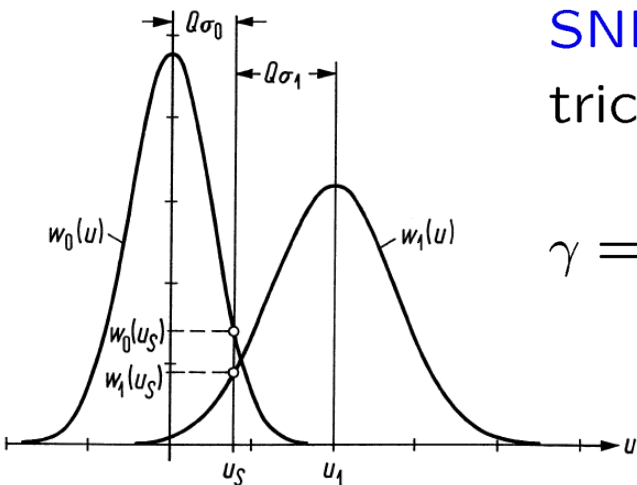
$$P = \frac{1}{2} \left\{ \frac{1}{T_t} \int_{-T_t/2}^{+T_t/2} \overbrace{[u_1 h_A(t) + \underbrace{u_{R1}(t)}_{u_{R1}=0}]^2}_{u_{R1}=0} dt + \frac{1}{T_t} \int_{-T_t/2}^{+T_t/2} u_{R0}^2(t) dt \right\}$$

$$= \frac{u_1^2}{2} I(h_A) + \frac{1}{2} (\sigma_0^2 + \sigma_1^2), \quad I(h_A) = \frac{1}{T_t} \int_{-T_t/2}^{+T_t/2} h_A^2(t) dt \approx \frac{1}{2}$$

SNR follows, with  $u_1 = (\sigma_0 + \sigma_1)Q$  and electrical signal power  $P_S$  to noise power  $P_R$ :

$$\gamma = \frac{P_S}{P_R} = \frac{u_1^2 I(h_A) / 2}{(\sigma_0^2 + \sigma_1^2) / 2} = Q^2 \frac{(\sigma_0 + \sigma_1)^2 I(h_A)}{\sigma_0^2 + \sigma_1^2}$$

$$= (0.97 \dots 1) \times Q^2, \rightarrow \gamma = \frac{P_S}{P_R} = Q^2$$

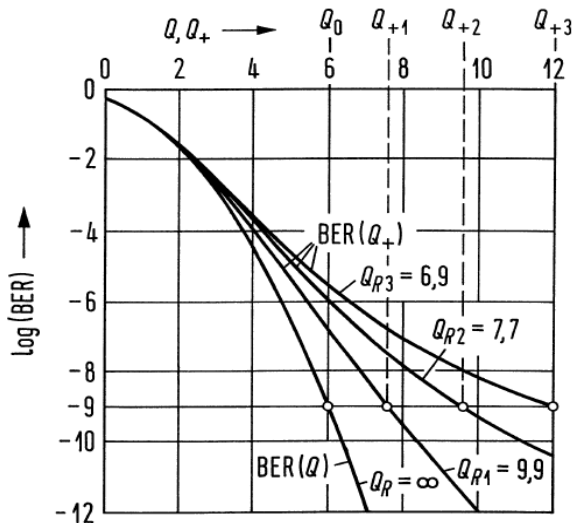


# BER and Power Penalty (1)

Compensation of additional noise (noise power  $P_{Rz}$ ) by an increase of signal power  $P_S \rightarrow P_{S+}$  possible?

$$\gamma = Q^2 = \frac{P_S}{P_R} = \frac{P_{S+}}{P_R + P_{Rz}}, \quad \gamma_+ = Q_+^2 = \frac{P_{S+}}{P_R}, \quad \text{BER}_+ = \frac{1}{2} \text{erfc} \left( \frac{Q_+}{\sqrt{2}} \right)$$

$\gamma_+$ ,  $Q_+$ ,  $\text{BER}_+$  for  $P_{S+}$  without additional noise.



**Additive noise:** Compensation by increase of opt. input power  $P_{\text{opt}}$  always possible. El. signal  $P_S \sim (P_{\text{opt}})^2$ . Power penalty:

$$\begin{aligned} p_B &= 10 \lg \left( \frac{P_{\text{opt}+}}{P_{\text{opt}}} \right) = 5 \lg \left( \frac{P_{S+}}{P_S} \right) \\ &= 10 \lg \left( \frac{Q_+}{Q} \right) = 5 \lg \left( 1 + \frac{P_{Rz}}{P_R} \right) \end{aligned}$$

**Fig. 7.4.** Bit error probability from Eq. (7.27) as a function of the bit error parameters  $Q$  (denoted as  $\text{BER}(Q)$ ) and  $Q_+$  (denoted as  $\text{BER}(Q_+)$ ) for various values of the residual bit error parameter  $Q_R$

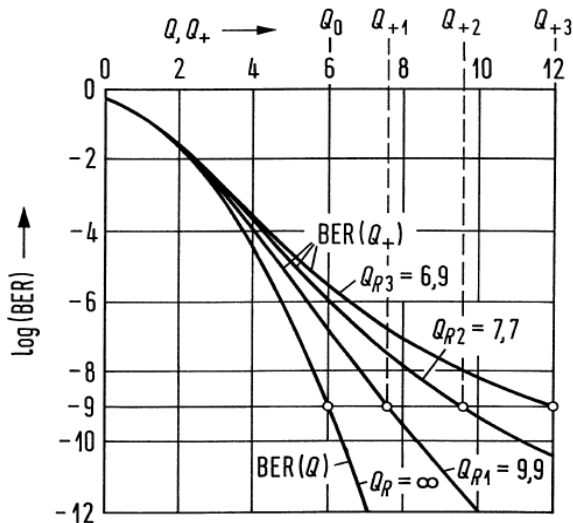


## BER and Power Penalty (2)

**Multiplicative noise:** Noise power  $P_{Rz} = \frac{1}{\gamma_R} \cdot P_S = \frac{1}{Q_R^2} \cdot P_S$  compensatable by increased signal power  $P_S \rightarrow P_{S+}$ ?

$$\gamma = Q^2 = \frac{P_S}{P_R} = \frac{P_{S+}}{P_R + P_{Rz}} = \frac{P_{S+}}{P_R + P_{S+}/Q_R^2} = \frac{Q_+^2 Q_R^2}{Q_+^2 + Q_R^2} \xrightarrow{P_{S+} \rightarrow \infty} Q_R^2$$

$\gamma_+$ ,  $Q_+$ ,  $\text{BER}_+$  for  $P_{S+}$  without additional noise.



Compensation with increased opt. input power  $P_{\text{opt}}$  not complete. El. signal  $P_S \sim (P_{\text{opt}})^2$ . Power penalty, floor BER:

$$p_B = 10 \lg \left( \frac{P_{\text{opt}+}}{P_{\text{opt}}} = \frac{Q_+}{Q} \right) = 5 \lg \left( \frac{Q_R^2}{Q_R^2 - Q^2} \right),$$

$$\text{BER}_R = \frac{1}{2} \text{erfc} \left( \frac{Q_R}{\sqrt{2}} \right)$$

**Fig. 7.4.** Bit error probability from Eq. (7.27) as a function of the bit error parameters  $Q$  (denoted as  $\text{BER}(Q)$ ) and  $Q_+$  (denoted as  $\text{BER}(Q_+)$ ) for various values of the residual bit error parameter  $Q_R$





# Limiting Sensitivity for Direct Detection (1)

No electron. noise. PD  $\eta = 1$ . Zero:  $\overline{N_{e0}} = 0$ . One:  $\overline{N_e} \neq 0$ . Prob.  $p(1d|0r) = 0$  that 0 wrongly detected as 1. Threshold  $u_S \rightarrow u_S = 0$ . Only logical 1 perturbed,  $p(0d|1r) \neq 0$ . Poisson probability of photons:

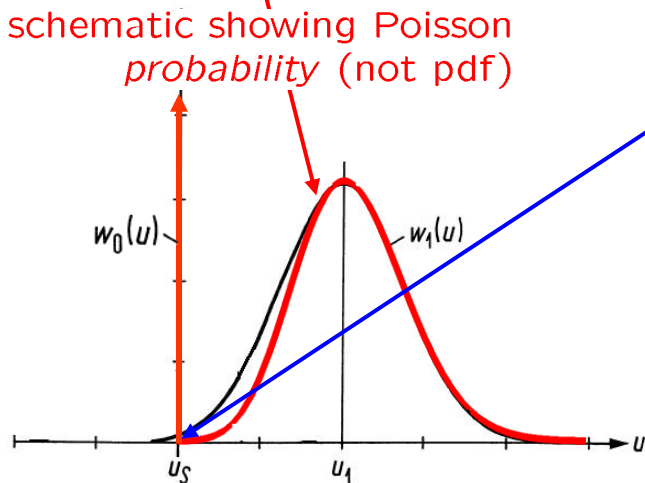
$$p_{N_e}(N_e) = \frac{\overline{N_e}^{N_e}}{N_e!} e^{-\overline{N_e}}, \quad \overline{\delta N_e^2} = \overline{N_e}, \quad (\overline{N_e} \text{ arbitrary})$$

$p_{N_S}(N_e = 0)$  is probability that logical 1 with  $\overline{N_e} > 0$  wrongly detected as logical 0:

$$p_{N_e}(0) = \frac{\overline{N_e}^0}{0!} e^{-\overline{N_e}} = e^{-\overline{N_e}} > 0$$

Poisson probability is discrete, therefore probability density function:

$$w_{N_e}(N_e) = \sum_{N'_e=0}^{\infty} p_{N_e}(N_e) \delta(N_e - N'_e)$$





## Limiting Sensitivity for Direct Detection (2)

Prob. One:  $p(1r) = 1/2$ . Because of Poisson statistics, prob. that One  $\rightarrow$  Zero:  $p(0d|1r) = p_{N_{e1}}(0) = e^{-\overline{N}_e}$ . BER:

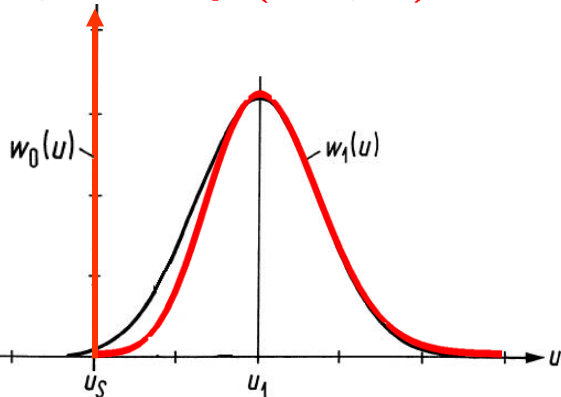
$$\text{BER} = \underbrace{\frac{1}{2}}_{p(1r)} \underbrace{\exp(-\overline{N}_e)}_{p(0d|1r)} + \underbrace{\frac{1}{2}}_{p(0r)} \underbrace{0}_{p(1d|0r)}, \quad \rightarrow \quad \boxed{\text{BER} = \frac{1}{2} e^{-\overline{N}_e}}$$

$$p(0r) + p(1r) = 1,$$

For bit error probability  $\text{BER} = 10^{-9}$  therefore:

$$\overline{N}_e = -\ln(2 \times 10^{-9}) = 20 \quad \rightarrow \quad \boxed{\overline{N}_e = 20 \quad \text{for} \quad \text{BER} = 10^{-9}}$$

schematic showing Poisson probability (not pdf)



Photons for One ( $w(1r) = 1/2$ ). On average:

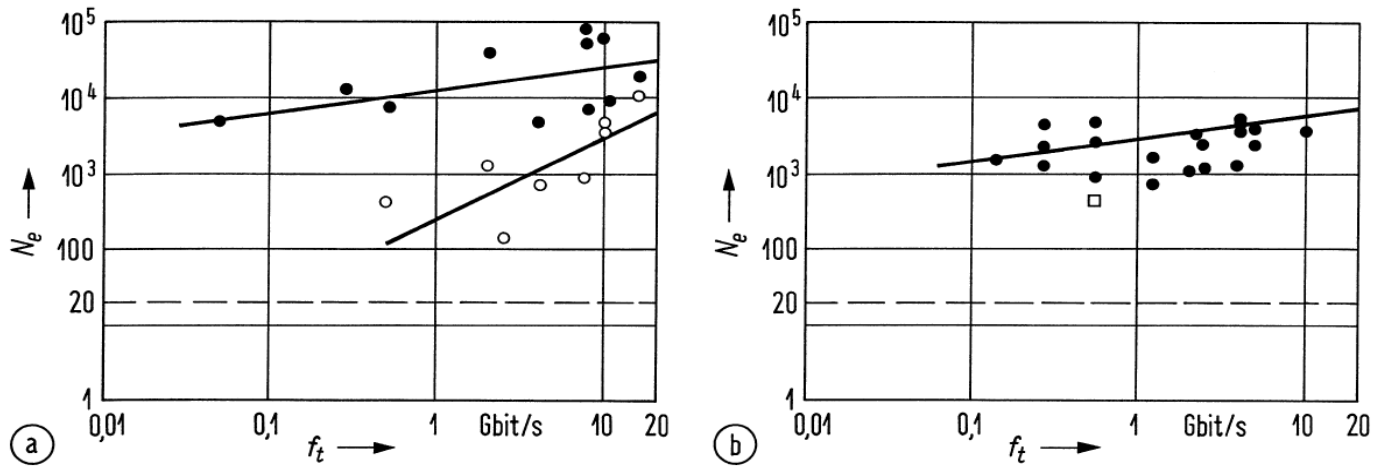
$$\overline{N}_{e \text{ bit}} = \underbrace{20}_{\overline{N}_e} \underbrace{\frac{1}{2}}_{p(1r)} + \underbrace{0}_{\overline{N}_{e0}} \underbrace{\frac{1}{2}}_{p(0r)}$$

$$\overline{N}_{e \text{ bit}} = 10 \quad \text{for} \quad \text{BER} = 10^{-9}$$

Realized:  $N_{e \text{ bit}} = 4\,000$  (pin-PD),  
 $N_{e \text{ bit}} = 150$  (APD), 152 (pin & OA)



# Measured Sensitivities for Direct Detection



**Fig. 7.5.** Measured minimum received photon numbers  $N_e$  for a 1 bit ( $\eta$  not known,  $\text{BER} = 10^{-9}$ ). Quantum limit  $N_e = 20$ ,  $\eta = 1$  (---). (a) pin-photodiode  $\lambda = 1.3$ ;  $1.55 \mu\text{m}$  (●), pin-photodiode with optical amplifier (○) (b) avalanche photodiode (APD)  $\lambda = 1.55 \mu\text{m}$  (●),  $\lambda = 0.85 \mu\text{m}$  (□)



# END OF LECTURES

